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FOREWORD

This volume is the third of five volumes which contain contributed papers that were accepted by the Local Organizing Committee of the XXIII ICPIG for presentation in poster sessions. These papers are to be listed in the INSPEC data base.

The contributions were submitted in camera-ready form by the authors. Therefore, the responsibility for the contents and the form of the papers rests entirely with the authors.

The first four volumes have been arranged by topics, the sequence of which corresponds to that of the respective poster sessions. The fifth volume is comprised of 'late' papers, those for which the authors registered after the deadline for printing of their papers.

The texts of the invited talks are to be published shortly after the conference in a special issue of *Journal de Physique*.

The editors would like to acknowledge the contributions of Mrs L. Fourmeaux, Mr J.M. Barachet and Mr J.P. Chauchepat in the preparation of these volumes. The computer file of contributed papers and authors was prepared by C. de Peco, and her careful execution of this task is gratefully acknowledged.

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The Editors

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Topic 7

**Ionospheric, magnetospheric and
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MODELLING OF PULSE FLUCTUATION REFLECTOMETRY IN FUSION AND SPACE PLASMAS

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1. Introduction

The reflectometry is widely used in plasma fusion and in space plasmas as a tool. For fusion plasmas, it is wellknown that density fluctuations induce errors on the density profile reconstruction which may lead in some cases to unrealistic profiles[1]. In space plasma physics, the backscattered pulse due to artificial irregularities (PAI) are used to evaluate some plasma parameters. The present work has two aims. First, it studies some effects of coherent density fluctuations on the profile reconstruction; specifically, it focuses on the role of resonant Bragg backscattering (i.e. there is a resonant condition $k_f = 2 * k(x)$ between the local incident wavenumber $k(x)$ and the fluctuation wavenumber k_f) in pulse reflectometry. Second, it gives a quantitative model of the behaviour of the wave backscattered in the ionospheric E region in the PAI experiment[2]. We have implemented a code which solves the wave propagation equation in one space dimension (particular cases with 2 space dimensions can be treated). This code describes either the O-mode in a magnetized plasma or the electromagnetic wave in an isotropic plasma. For each case, we discuss briefly about the choice of the inputs and the limitations of the simulation. Then, we conclude by a discussion on what the 1D code can do or cannot describe.

2. Basic equation and numerical method

The one-dimensional wave equation can be written:

$$\partial_t^2 E_z - c^2 \partial_x^2 E_z + \omega_{pe}^2 E_z = 0 \quad (1)$$

where E_z is a function of x and t and ω_{pe} depends on x only (i.e. the plasma is in a steady-state). Absorbing boundary conditions (no reflection at the boundaries)[3] are imposed on the edges of the numerical grid. The numerical method uses a centered finite difference scheme with a second-order accuracy for the D'Alembertian and splits the $\omega_{pe}^2 E_z$ in terms E_z taken at different times. The space step $\Delta x = c \Delta t$ (where Δt is the time step) satisfies the stability criterion for this scheme and permits to determine easily the initial conditions for a right-going pulse launched in vacuum. The numerical accuracy is consistent with the order of the numerical error. Under the assumptions mentioned before, the explicit scheme writes

$$E_{ij+1} = \frac{1}{1 + \omega_p^2(i)/4} \left\{ -\frac{\omega_p^2(i)}{2} E_{ij} + E_{i+1j} + E_{i-1j} \right\} - E_{i,j-1}$$

where the i and j indices represent space and time respectively. The initial conditions require that $E_{i,0}$ and $E_{i,1}$ be specified; for instance, in vacuum $E_{i,1} = E_{i,0}$. The outgoing conditions can be found in the reference [3].

3. Profile reconstruction with density fluctuations

Two distinct situations have been simulated with the use of appropriate initial conditions and diagnostics: (i) classical (CW) reflectometer, and (ii) pulsed radar reflectometer. For simplicity, to test the influence of density fluctuations on these systems, a linear density profile was chosen, although the results can easily be extended. Modulated (carrier wavenumber k_f) Gaussian density perturbations are used. The phase shift or time delay is computed for different frequencies, and an Abel inversion is performed to reconstruct the density profile.

For the classical reflectometer, the initial pulse L_p is long enough ($L_p > 4(x_c - x_0)$, (x_c and x_0 are the plasma cut-off and edge positions) so that the ingoing and outgoing parts of the pulse coexist all over the plasma. This long pulse propagative code has been compared to the (steady-state) Helmholtz code. We obtain the same results for the phase shift with or without density fluctuations. As in the Helmholtz case[4], spectral effects due to the width of the density perturbation are observed. The phase shift due to Bragg backscattering is either the image of the density perturbation itself (spatial regime) or the image of its Fourier transform (spectral regime). In the spatial regime, the phase shift varies like $L_g^{1/2}$, where L_g is the gradient length. For $L_g \sim 50\lambda_0$, density fluctuations begin to modify the profile reconstruction if their level is greater than $\sim 10\%$.

For the pulsed radar reflectometer, there is an optimal pulse length τ_{opt} which minimizes the reflected pulse length (this minimal length is twice the incident pulse length). This optimal length allows to determine the density gradient length at the cut-off position. For a linear density profile $\tau_{opt} = \sqrt{8 \ln 2 k_c L} / \omega_{p0}$. Spectral effects are also found in this case. Usually, in space plasma physics, the pulse width is greater than the optimal length, the reflected pulse is the image of the incident pulse (spatial case). The incident wavenumber spectrum is narrow so the Bragg backscattering process is sharply localized and only a narrow frequency band leads to perturbations of the reconstructed profile. Typically, if one assumes that the time delay is defined by the maximal amplitude of the reflected pulse, the reconstructed profile is modified by the density

fluctuations when their level is $\sim 10\%$. Figures 1 and 2 show respectively the pulse shape and the profile obtained in such a case. A lower threshold would lead to a greater influence of the fluctuations. Long wavelength perturbations near the cutoff do not backscatter the wave, but they can also induce large modifications of the time delay.

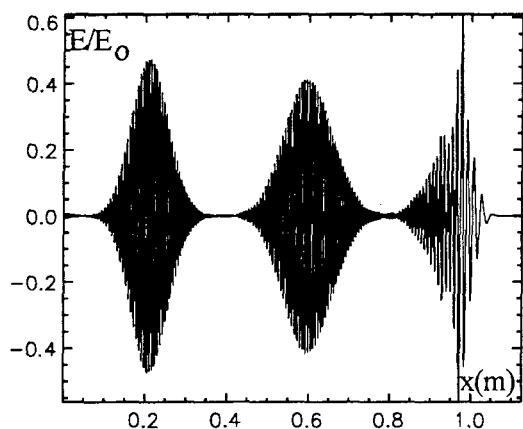


Fig1. Shape of the reflected pulse with $\Delta n/n \approx 10\%$. Backscattering corresponds to the leftmost pulse.

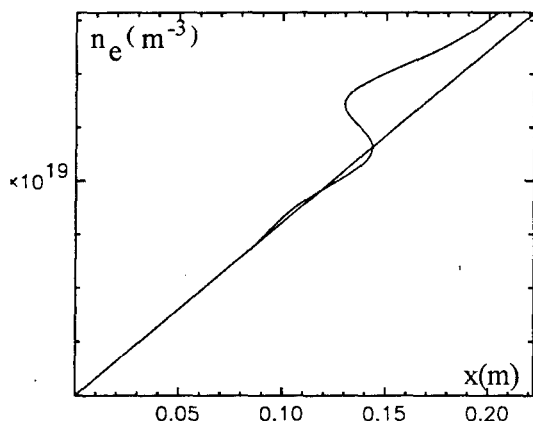


Fig 2. Comparison of the reconstructed profiles with and without fluctuation

4. Modelling of the PAI experiment

In this experiment the ionosphere is heated by a large amplitude quasicontinuous (.1 s to 3 mn) HF wave that produces a nonlinear density perturbation. This perturbation is then analyzed by a radar pulse (50 μ s, spatial regime above mentioned). Assuming that

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- [2] G.I. Terina "Characteristics of signals scattered by artificial ionospheric turbulence" *J. Atmos. Teresr Phys.* **57** (1995) 273.
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electrons behave adiabatically in the ponderomotive potential, the nonlinear density perturbation is proportional to $E_z^2/(T_e(x)+T_i(x))$. It can be obtained by solving iteratively the 1D Helmholtz equation, where the first iteration starts with the day-time density and temperature profiles of the ionosphere. The resulting perturbed profile is then introduced in the 1D propagative wave equation that models the probing wave. The iterated Helmholtz equation shows that the nonlinear density perturbation is larger in the E-layer, since the temperature is lower in this region. Accordingly the propagative wave equation gives a significant backscattered pulse coming mainly from the E-region, since the nonlinear density perturbation satisfies the Bragg rule everywhere. Figure 3 gives the behaviour of the received pulse. Furthermore, at large fluctuation amplitude, there is a nonlinear broadening of the Bragg rule $k_f=2k(x)$, that is, the probing frequency can be slightly different from the heating frequency.

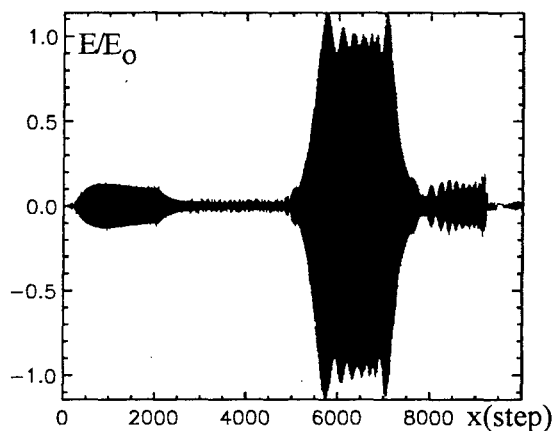


Fig 3. Backscattered pulse shape versus time in simulated PAI experiment

However the iterative method of solution of the nonlinear Helmholtz equation can be used only for moderate nonlinearity. This 1D analysis can be extended to the spherically symmetrical case. The $1/r$ decay of the field amplitude shifts the maximal nonlinearity towards lower altitudes, hence the Bragg backscattering from the E-region is even more pronounced.

A study of sub- to supersonic outflow of helium from polar regions

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1. Introduction

In polar regions where magnetic field lines are open a continuous outflow of light ions takes place (polar wind, [1], [2]). In particular, helium released from radioactive decay in the Earth crust eventually, when ionized, may be transported away in this way from the Earth atmosphere. The acceleration force upwards is the ambipolar electric field set up by electrons and heavy ions (in particular oxygen) in the upper atmosphere, and counteracting this force both the gravitation and the friction force from the background gas, together with pressure, play an important role. In the model presented we use a special method to show how helium ions are accelerated to supersonic velocity upwards. In particular we study the relative influence of the different forces and the position of the sonic point with varying parameter values.

2. Model

The model equations for the helium fluid are obtained by taking velocity moments of the kinetic equation. We use a Fokker-Planck collision term for light helium ions of mass m interacting with heavy oxygen ions (subscript '2'). Other collisional interactions are neglected in this model. The collision term is simplified assuming a large mass ratio m_2/m , and hence energy exchange between light and heavy ions is neglected.

2.1 Conservation equations

We further limit the set of equations for the helium fluid to equations only for number density n , fluid velocity u in the z -direction and temperature T , i.e. a 5(3) moment approximation. Thus we obtain the continuity equation,

$$u \frac{dn}{dz} + n \frac{du}{dz} = 0,$$

the momentum equation

$$\kappa T \frac{dn}{dz} + nmu \frac{du}{dz} + \kappa n \frac{dT}{dz} = \frac{T_e}{(T_e + T_2)} \frac{GMm_2 n}{(R + z_0 + z)^2} - \frac{MGm}{(R + z_0 + z)^2} - K \exp\left\{-\frac{GMm_2}{\kappa(T_e + T_2)(R + z_0)}\left(1 - \frac{R + z_0}{R + z_0 + z}\right)\right\} \frac{nu}{(T^{3/2} + \frac{m}{2\kappa} T^{1/2} u^2)}$$

where $K = \frac{4\pi}{3} \Gamma m (\frac{m}{2\pi\kappa})^{3/2} n_{20}$, and the (reduced) energy equation,

$$mu \frac{du}{dz} + \frac{5}{2} \kappa \frac{dT}{dz} = \frac{T_e}{(T_e + T_2)} \frac{GMm_2}{(R + z_0 + z)^2} - \frac{GMm}{(R + z_0 + z)^2}$$

R is Earth radius, z_0 the lower edge or baseheight (subscript '0') of the region in the ionosphere we study, and z the height above this level. T_2 and T_e are the oxygen and electron temperatures (both assumed

constant), and n_{20} the oxygen density at the lower edge. G, M, Γ and κ are respectively the Gravitational constant, the Earth mass, the Coulomb logarithm and the Boltzmann constant. The terms on the right hand side of the momentum equation are respectively the ambipolar electric force field set up by electrons and heavy ions, the gravitation force and the friction force due to helium-oxygen interactions. The energy equation shows the interplay between directional- and thermal-energy and electric- and gravitational energy of helium ions.

2.2 Integrating through the singularity

Non-dimensional variables $\xi = \frac{z}{z_0}, \rho = \frac{n}{n_0}, \omega = \frac{u}{u_s}$ and $\tau = \frac{T}{T_0}$ are introduced where $u_s = \sqrt{\frac{\kappa T_0}{m}}$ is a sonic speed of helium. The set of equations may be put on the non-dimensional form, $A \cdot \frac{d\sigma}{d\xi} = \mathbf{b}$, or

$$\begin{pmatrix} \omega & \rho & 0 \\ \tau & \rho\omega & \rho \\ 0 & \omega & \frac{\xi}{2} \end{pmatrix} \cdot \frac{d}{d\xi} \begin{pmatrix} \rho \\ \omega \\ \tau \end{pmatrix} = \begin{pmatrix} 0 \\ \frac{A\rho}{(r+1+\xi)^2} - \frac{B\rho}{(r+1+\xi)^2} - C \exp\{-D(1 - \frac{r+1}{r+1+\xi})\} \frac{\rho\omega}{r^{3/2} + \frac{1}{2} r^{1/2} \omega^2} \\ \frac{A}{(r+1+\xi)^2} - \frac{B}{(r+1+\xi)^2} \end{pmatrix}$$

On the right hand side the constants A, B, C and D ,

$$A = \frac{T_e}{T_e + T_2} \frac{GMm_2}{\kappa_0 T_0}, B = \frac{GMm}{\kappa_0 T_0}, C = \frac{\Gamma m^2 2^{1/2} n_2 n_{20}}{\pi^{1/2} \kappa^2 3 T_0^2}, D = \frac{GMm_2}{\kappa_0 (T_e + T_2)}$$

express the order of magnitude of the forces acting on the helium ions, and $r = \frac{R}{z_0}$. From Cramer's rule,

$$\frac{d\sigma_i}{d\xi} = \frac{N_i(\xi, \sigma)}{\Delta(\sigma)}, i = 1..3, \text{ where } \Delta(\sigma) = \det(\mathbf{A})$$

and $N_i(\xi, \sigma)$ are similar determinants except that vector \mathbf{b} replaces the i 'th column. The system of equations is singular when $\Delta = \frac{\rho}{2} (3\omega^2 - 5\tau)$ equals zero, i.e. when $\omega = \omega_s = (\frac{5}{3} \tau_s)^{1/2}$, the sonic speed of helium ions. For a solution to exist at the sonic velocity also the $N_i(z, \sigma), i = 1..3$, must be equal zero there. A remarkable property of the system of equation is that when $\Delta(\sigma) = 0$ and $N_i(z, \sigma) = 0$ for one of $i = 1..3$, then all the other $N_i(z, \sigma)$ equal zero also, [3].

The equations are transformed into an autonomous form of 4 equations of 4 unknowns (z, σ) by setting, [3],

$$\frac{dz}{dt} = \Delta(\sigma), \frac{d\sigma_i}{dt} = \frac{d\sigma_i}{dz} \frac{dz}{dt} = N_i(z, \sigma), i = 1..3$$

thus formally transforming the singularity into an equilibrium point in the (z, σ) -space. A closer study of solutions of the 4 equations in the neighborhood of the singularity in the (z, σ) -space reveals the equilibrium point is a saddle point in a two-dimensional subset of the 4 dimensional (z, σ) -space. Two solutions pass exactly through the singularity, one from sub- to supersonic velocity, and one from super- to subsonic velocity. The position of the singular (sonic) point (subscript 's') is given for instance by $N_1(z, \sigma) = 0$, i.e. by the zero of the function

$$\varphi(\xi_s) = \frac{3}{2} \frac{A}{(r+1+\xi_s)^2} - \frac{3}{2} \frac{B}{(r+1+\xi_s)^2} - C \exp\left[-D\left(1 - \frac{r+1}{r+1+\xi_s}\right)\right] \frac{2\sqrt{15}}{11} \frac{1}{\tau_s}$$

3. Solutions

We seek solutions passing through the singularity, and let $z_0 = 250\text{km}$. This is approximately the position of maximal ion density. $n_{2,0}$, the oxygen ion and electron density, is set to $10^{10} / \text{m}^3$, the electron and oxygen ion temperatures to $T_e = 3000\text{K}$ and $T_2 = 1000\text{K}$, respectively. For the helium ion fluid we use the following boundary conditions at the lower edge $\xi = 0$: $\rho(0) = 1$, $T(0) = T_0 = 1000\text{K}$, $\rho(0)\omega(0) = \omega(0) = F$, the constant flux, and $\tau(0) = 1$. The position of the singular point is found from $\varphi(\xi_s) = 0$ and a value of τ_s in this equation that matches the boundary condition $\tau(0) = 1$ when integrating from the singularity to $\xi = 0$. The direction of the solutions through the singularity is found from solving a linearized version of the fluid equations in a neighborhood of the singularity. When τ_s is determined, and hence ω_s , using $\omega(0)$ and the flux F , the helium density at ξ_s becomes $\rho(\xi_s) = \frac{\omega(0)}{\omega(\xi_s)}$.

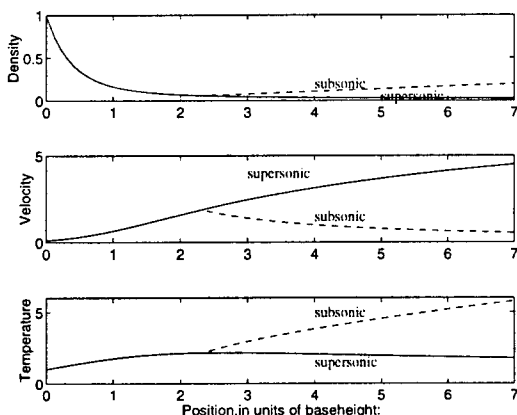


Fig.1: Non-dimensional density, velocity and temperature of vertically flowing helium with parameter values as given in text.

Fig. 1 shows typical results from calculations, and Fig. 2 depicts the corresponding sum of accelerating forces. Both physical solutions that pass smoothly through the singularity (full line), and non-physical solutions (dashed) are shown. The singularity is at $\xi_s = 2.3$.

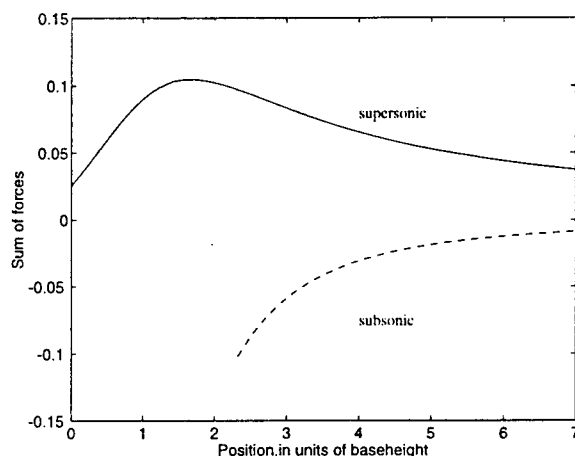


Fig.2. Sum of non-dimensional forces per unit volum. Parameter values as given in text.

We study how the position of the singularity varies with parameters $n_{2,0}$, T_e , T_2 and T_0 in A, B, C and D related to the different forces:

- (i) Varying $n_{2,0}$ from $5 \cdot 10^9 / \text{m}^3$ to $10^{11} / \text{m}^3$, ξ_s grows from 1.5 to 4.4: As oxygen density rises friction increases, and the helium ions have to accelerate over longer distance to reach the sonic point.
- (ii) Varying T_e from 1000K to 5000K: As T_e increases, the diffusion of electrons increases relative to ions, and the ambipolar electric field increases. However, the oxygen density will decrease more slowly with height. Hence up to $T_e = 1400\text{K}$ ξ_s falls from approximately 1.75 to 1.65. Here the growth of the electric field dominates the acceleration. From 1400K upwards ξ_s grows to 2.65. Here the increased oxygen density, and hence friction, dominates.
- (iii) Varying T_2 from 1000K to 2800K, the value of ξ_s rises steadily from approximately 2 to 5.75. This is because the diffusion of oxygen ions rises and reduces the ambipolar field and also leads to a slower decrease of the oxygen density with height.
- (iv) Varying T_0 from 500K to 2000K, the value of ξ_s decreases in a monotonic way: The decrease is due to lower collision frequency $\nu = \frac{\Gamma_{2s}}{v}$ with increasing temperature, and hence lower friction, and the helium accelerates to the sonic velocity over shorter and shorter distances.

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Nonlinear whistler wave scattering in space plasmas

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1. Introduction

In this paper the evolution of nonlinear scattering of whistler mode waves by kinetic Alfvén waves (KAW) in time and two spatial dimensions is studied analytically. We suggest this nonlinear process as a mechanism of kinetic Alfvén wave generation in space plasmas. This mechanism can explain the dependence of Alfvén wave generation on whistler waves observed in magnetospheric and ionospheric plasmas. The observational data [1,2] show a dependence for the generation of long periodic pulsations Pc5 on whistler wave excitation in the auroral and subauroral zone of the magnetosphere. This dependence was first observed by Ondoh T. I. [1]. For 79 cases of VLF wave excitation registered by Ondoh at College Observatory (L=64.6 N), 52 of them were followed by Pc5 geomagnetic pulsation generation. Similar results were obtained at the Loparskaia Observatory (L=64 N) [2] for auroral and subauroral zone of the magnetosphere. Thus, in 95% of the cases when VLF wave excitation occurred the generation of long periodic geomagnetic pulsations Pc5 were observed. The observations also show that geomagnetic pulsations Pc5 are excited simultaneously or insignificantly later than VLF waves [2]. In fact these two phenomena are associated genetically: the excitation of VLF waves leads to the generation of geomagnetic pulsations Pc5 [2]. The observations [3] show intensive generation of geomagnetic pulsations during thunderstorms. Using an electromagnetic noise monitoring system covering the ULF range (0.01-10 Hz) A.S. Fraser-Smith observed intensive ULF electromagnetic wave during a large thunderstorm near the San-Francisco Bay area on September 23, 1990. According to this data the most significant amplification in ULF wave activity was observed for waves with a frequency of 0.01 Hz and it is entirely possible that stronger enhancements would have been measured at lower frequencies.

2. Theoretical results

We use two-fluid magnetohydrodynamics and kinetic plasma theory to describe three wave interactions. We consider the parametric decay of a whistler wave WW into a KAW and another whistler wave:

$$WW \rightarrow WW + KAW$$

We assume that the process takes place in a locally uniform plasma with a uniform magnetic field because the wave length of the interacting waves is less than the scale size of the background ionospheric plasma inhomogeneity by about three order of magnitude. We select the direction of magnetic field line to be parallel to the z-axis of a Cartesian system of coordinates. The conservation of energy and momentum in this process is reflected in the frequency and wave vector matching conditions:

$$\begin{aligned}\omega_0 &= \omega_1 + \omega_A \\ \vec{k}_0 &= \vec{k}_1 + \vec{k}_A\end{aligned}\quad (1)$$

Where ω_0, k_0 are the frequency and wave vector of whistler pump wave; ω_1, k_1 are the frequency and wave vector of scattered WW; ω_A, k_A are the frequency and wave vector of the KAW. For the case when the plasma parameter $\beta \ll 1$, the electric field of the KAW can be written:

$$\vec{E}_A = -\vec{\nabla}\varphi_A - \frac{1}{c}\frac{\partial}{\partial t}A_z\vec{e}_z\quad (2)$$

By using the set of two - fluid MHD equations we obtain the dispersion equation for KAW coupling with whistler waves:

$$\eta_A \varphi_A = \mu_A E_0 E_1^* \quad (3)$$

Where E_0 is the electric field of whistler pump

wave; $\eta_A = \omega_A^2 - k_{Az}^2 V_A^2 (1 + k_{Ax}^2 \rho_s^2)$

From the set of two - fluid MHD equations we obtain dispersion equation for WW coupling with KAW and whistler pump wave:

$$\eta_1 \varphi_1 = \mu_1 E_0 \varphi_A^* \quad (4)$$

Where $\eta_1 = \omega_1^2 - c^4 k_1^2 k_{1z}^2 \omega_{Be}^2 / \omega_{pe}^2$

and μ_A, μ_1 are the coupling coefficients.

We solved this system of nonlinear dispersion relations (3,4) numerically taking into account

the frequency and wave vector matching conditions (1), and attenuation factors for KAWs and WVs known from kinetic plasma theory, and assuming an amplitude for the whistler pump wave of $E=1$ mV/m, for the typical ionospheric plasma parameters at an altitude of 300 km. The dependence of the instability growth rate on the angle between the whistler pump wave vector and the geomagnetic field line is shown in Fig. 1.

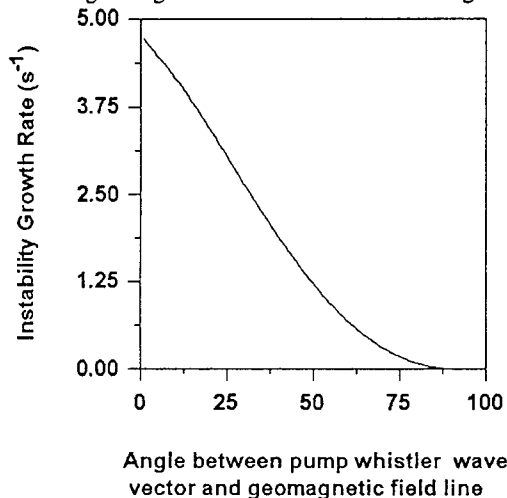


Fig. 1

Figure 2 shows the dependence of the instability growth rate on the angle between the scattered whistler wave vector and the geomagnetic field line.

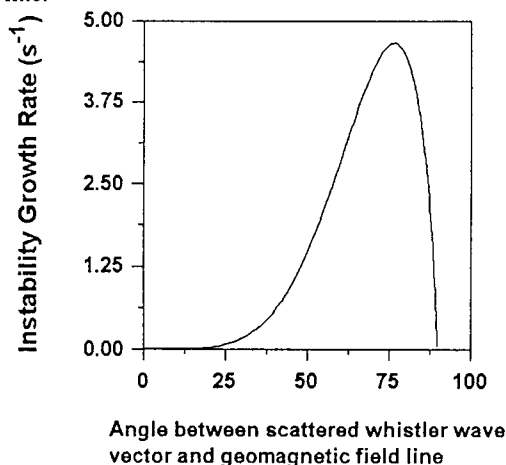


Fig. 2

3. Discussion and conclusion

Using a two-fluid MHD approach to study three wave interactions of whistler mode waves with

KAWs (which can interact with other types of waves much more efficiently than MHD Alfvén waves because of the presence of a longitudinal electric field component for the KAW [4,5]) we conclude that VLF whistler waves can be scattered by ULF kinetic Alfvén waves, and that the latter will be enhanced in such cases. The amplification of ULF waves is indeed observed during thunderstorms, simultaneously with excitation of VLF electromagnetic radiation [3]. Some recent satellite observations also show the presence of KAWs in the magnetosphere and in the topside of the ionosphere [6,7]. In the magnetosphere the long-periodical geomagnetic pulsation generation dependence on whistler waves is observed as well. This dependence was first noted in [1]. Similar results were obtained for the subauroral zone in [2]. In the auroral zone the geomagnetic pulsation generation was observed simultaneously or later than whistler excitation. It can be concluded that whistler excitation in the magnetosphere leads to long-periodical geomagnetic pulsation generation. The mechanism discussed in this paper can be applied for the case of whistler wave propagation in the magnetosphere as well.

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Generation of Elves by Sprites and Jets

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1. Introduction

Recent years of observations of the upper atmosphere and the lower ionosphere brought a fascinating collection of new phenomena including optical, radio, and gamma-ray emissions originating in the 20 to 90 km altitude range. Up to now, the most diverse phenomenology has emerged from the optical observations which have led to the identification of red sprites, blue jets, blue starters, e.g. [1-4], and elves, e.g. [5], [6]. Most of the studies have concentrated on relating such phenomena in the upper atmosphere to regular lightning discharges in the troposphere. For example, sprites and jets are believed to be optical manifestations of electrical discharges in the upper atmosphere caused by quasi-electrostatic fields penetrating to high altitudes during a regular lightning discharge. The sprite/jet discharge itself can be caused by the runaway air breakdown, e.g. [7], or regular air breakdown [8]. The standard theory [9] for optical airglow transients [5] in the lower ionosphere above the thunderstorms also known as elves [6] suggests that they are produced during interaction of electromagnetic pulses (EMP) from lightning with the lower ionosphere. Heating of the ambient electrons by the EMP in the D region can result in excitation of optical emissions once the optical excitation thresholds are reached. In this paper we suggest that in addition to this mechanism [9] elves can be caused by an EMP generated by sprites and jets. If sprites and jets are indeed accompanied by electrical discharges then some energy of their EMPs reaches to the ionosphere and heats ambient electrons there that in turn stimulates optical emissions similar to EMPs from regular lightning.

2. Model

In our description of the model we will refer to Figure 1. Let us start from the moment when a regular cloud to ground discharge occurs. At this time an EMP from lightning (L-EMP) is generated followed by quasi-electrostatic (QE) fields that are established in the upper

atmosphere. When a L-EMP reaches to the ionosphere it can generate optical emissions in that region known as elves [6]. In the model that we consider sprites and jets are produced by the runaway discharge mechanism, e.g. [7] and other papers at this conference from our group, that is developed from cosmic ray seed MeV electrons in the presence of QE-fields. Such sprite/jet discharges generate their own EMP (SJ-EMP) that reaches the ionosphere and can generate optical emission in the same manner as a L-EMP does.

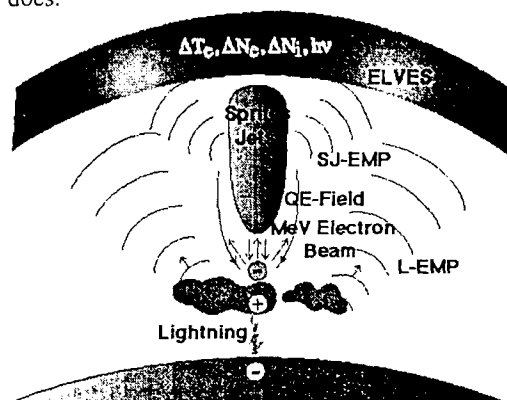


Figure 1. Comparison of lightning and sprite/jet mechanisms of elves generation.

The proximity of sprites/jets to the lower ionosphere means that in their case the power of an EMP could be several times lower than the power of a L-EMP and still cause generation of elves comparable in brightness to the ones generated by a L-EMP.

3. Results

The results of our computations indicate that the typical time duration of a SJ-EMP is 100 to 200 μ s, for figure see Yukhimuk et al. at this conference. Such duration is comparable to duration of a L-EMP. Figure 2 shows dependence of the maximum electric field of a SJ-EMP at the altitude of 80 km versus radius. Duration of the stimulating lightning discharge was 5 ms. To draw conclusions concerning the generation of optical emissions by an EMP with such electric field at the bottom of the ionosphere we refer to paper [9] where it is shown that an

EMP with about 100 μs duration and an electric field amplitude larger than 20 V/m is sufficiently potent to produce optical emissions with intensities twice that of the nighttime background. From the radial distribution of electric field in Figure 2 we conclude that the emissions are generated in the region between two radii where the condition $E > 20$ V/m is satisfied.

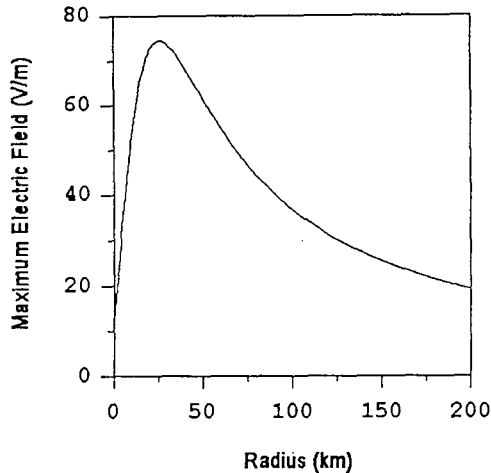


Figure 2. Distribution of maximum electric field of SJ-EMP versus radius. Duration of the driving lightning discharge is 3 ms.

Figure 3 summarizes results on the maximum electric field of a SJ-EMP and the radius of elves generated by such an EMP as a function of lightning duration. At this point we give rough estimates of these parameters. When the driving lightning discharge is slow (> 7 ms) a SJ-EMP becomes weak and we do not expect generation of elves for such cases.

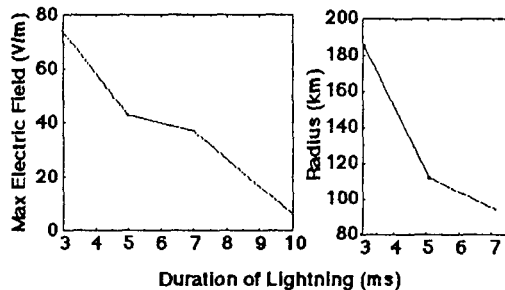


Figure 3. Maximum electric field of sprite/jet EMP at the altitude of 80 km and the expected radius of elves.

4. Conclusions

Our simulations demonstrate that sprites/jets driven by the runaway air breakdown mechanism

can generate a powerful EMP that can stimulate transient airglow brightenings in the lower ionosphere also termed elves [6]. The sequence of events involved in this process is the following: *i*) an atmospheric cloud to ground or intracloud discharge occurs that leads to *ii*) establishment of strong QE fields in the upper atmosphere, *iii*) where runaway air breakdown [7] is stimulated by ambient cosmic rays, *iv*) such a discharge can produce a strong EMP with duration of 100 to 200 μs that is predominantly upward directed due to the relativistic nature of the source [10], *v*) the EMP in turn can produce optical emissions, perturbations of electron density and chemical perturbations in the lower ionosphere [9]. We find that parameters of a SJ-EMP are similar to those produced by regular lightning which makes it difficult in observations to distinguish an EMP produced by two different sources: lightning and sprites/jets. This fact makes the picture of electromagnetic interactions in the atmosphere more rich and fascinating.

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HF Echoes from Ionization Potentially Produced by High-Altitude Discharges

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1. Introduction

In this paper we report on recent radar measurements taken during the month of October 1994 with the LDG HF radar in the Ivory Coast, Africa as part of the International Equatorial Electrojet Year. The purpose of this experimental effort in part was to study the effects of thunderstorms on the ionosphere. At the same time, we decided to carry out a set of experiments of an exploratory nature to look for echoes that could potentially arise from ionization produced in the mesosphere. The two leading candidates for producing transient ionization in the mesosphere are meteors and high-altitude discharges. Each is discussed in the context of our measurements.

2. Experimental Setup

The R4FEL HF radar used in our experiments was developed at the Laboratoire de Détection et de Géophysique (LDG) of the Commissariat à l'Énergie Atomique (CEA). It was conceived by *Herbeteau* [1] and was installed at Korhogo, Ivory Coast (9°24'62" N, 5°39'38" W), for the International Equatorial Electrojet Year. This location is particularly well suited for studies of the equatorial ionosphere and lightning. The frequency of stormy days per month ranges from 20-25 during the April-October period [2], [3]. The LDG radar [4] operates in the frequency range from 1-30 MHz and is composed of two spiral antennas (each 100 m in diameter) for transmission and reception. At the frequencies used in these experiments the antenna lobe, full-width at half-maximum power is approximately 50°. However, the combination of antenna sensitivity, transmitted power, and low noise background in the Ivory Coast permits the

recording of echoes over a cone of approximately 140°. Two pulses separated by 50 μ s are transmitted at two different frequencies every 5-10 ms. This procedure permits management of two parallel elementary sounding cycles. The pulses have a Gaussian envelope with a selectable full-width at half-maximum of 10 - 20 μ s or 40 μ s and a peak power of 5 kW.

The large number of possible parameter- and task- combinations permits performance of a wide variety of investigations [4]. The experiments described in this paper used a specific 'lightning' mode that consists of envelope detection at one sounding frequency over a range of 1000 km. The time and range resolutions were 70 ms and 1.67 km, respectively.

Goniometer measurements of spherics were used to determine the location of thunderstorms. Sensors composed of two crossed-loop antennas with bandwidths of 1 kHz-8 MHz were used to detect lightning signals and to determine their angle-of-arrival. Data taken at two or more widely separated sites permitted identification of the source location. One sensor was placed at the main station D: Korhogo. Two additional stations B and C were located at 17 and 19 km from D with azimuthal directions BD and CD relative to magnetic north of 159° and 211°, respectively. The transmission of time-of-arrival and azimuthal data from stations B and C to the main station was performed using unidirectional radio links. If an event was detected by two or three stations, the location was determined. This system yields maps of storm positions within about 400 km of the main station.

3. Measurements

Experiments designed specifically to look for echoes from high-altitude discharges were

performed on five occasions over a period of ~10-15 minutes each. Two additional control experiments were performed after the thunderstorm season. Despite the measurements of Rumi [5] at high frequencies (28 MHz), we decided in this initial set of experiments to operate only at frequencies below 3 MHz in order to maximize our chances of obtaining an echo. One nighttime and two daytime cases clearly showed signatures that could be associated with ionization produced by lightning discharges. One additional daytime experiment showed evidence for oblique reflections originating at large ranges (several hundred kilometers). The remaining daytime experiments showed no evidence of isolated transient events or were contaminated by sporadic-E which made it difficult to identify such events.

In all cases, the radar was operated at 2.2, 2.5, and/or 2.8 MHz. The echoes turned on in several interpulse times of 70 ms and were generally correlated with strong lightning activity prior to onset. Returns lasted several hundred ms at night and 1 - >10 s during the day. The angles of arrival of spherics detected at three goniometer stations were used to determine the distance to thunderstorms.

Detailed range-time plots of the echoes will be presented for all cases along with goniometer maps showing the locations of lightning spherics as a function of time.

4. Interpretation

Two potential sources of transient ionization in the upper atmosphere are meteors and high-altitude discharges associated with thunderstorms. In the case of meteors, there are some basic inconsistencies between the characteristics of meteor echoes and our observations. At the most probable altitudes for meteor intercepts, ambipolar diffusion dominates the density decay and yet the data show a much longer event duration during the day than at night. Reflection virtual heights (of 82 km) that are much lower than the most probable heights were measured on occasion. Finally, the echoes identified in our measurements are correlated with lightning activity. High-altitude discharges termed sprites can produce significant transient ionization of the mesosphere according to theoretical calculations based on runaway air breakdown [6], [7], [see also, companion papers presented at this meeting]. A plot showing the computed electron

density profile along the symmetry axis of a sprite simulation is shown in Figure 1.

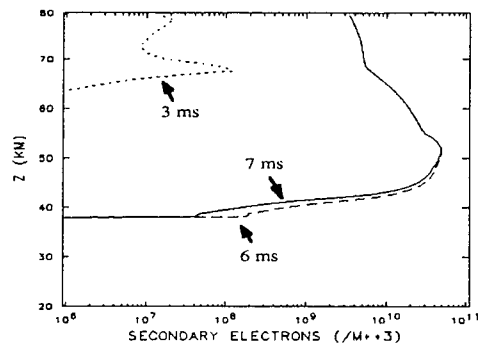


Fig. 1

The data are consistent with specular reflections from an ionization layer produced by a sprite like event at 55-65 km altitude and having minimum electron densities of $6 \times 10^4 - 10^5 \text{ cm}^{-3}$. The duration of the ionization is consistent with attachment, detachment, and recombination times in the nighttime and daytime mesosphere at these altitudes.

Detailed comparisons between theory and experiment will be presented along with ray-tracing calculations showing the detailed reflection geometry for a range of frequencies. The self-consistent temporal evolution of the full 2-d electron density profile is included in these calculations.

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High Altitude Atmospheric Discharges According to the Runaway Air Breakdown Mechanism

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1. Introduction

High altitude optical transients (see e.g. [1]) - red sprites, blue jets, and elves - are modeled in the context of the relativistic electron runaway air breakdown mechanism. These emissions are usually associated with large mesoscale convective systems (hereafter MCS). In thunderstorms cloud electrification proceeds over a time scale long enough to permit the conducting atmosphere above the cloud to polarize and short out the thunderstorm electric field. When a lightning strike rapidly neutralizes a cloud charge layer runaway driving fields can develop in the stratosphere and mesosphere. According to our simulations of the full runaway process the variety of observed optical emissions are due to the nature of the normal lightning event in the MCS that kick starts the runaway avalanche. In this paper we describe some details of the model, present the results of the evolution of the primary electron population, and summarize the initial conditions necessary for different types of discharges. Two companion papers present (a) the predicted optical, gamma ray, and radio emissions caused by these electrical discharges, and (b) the time evolution of the secondary electron population and its implications in terms of observables.

2. Theoretical results

In our simulations a quasi-electrostatic, multifluid approach similar to that of Taranenko and Roussel-Dupré [2] is used to model the relativistic (primary) electrons, secondary electrons and the positive and negative ions. The work includes, for the first time, the full time evolution of the runaway discharge. This evolution starts by resolving the initiating cloud-to-ground or intracloud discharge and continues to late times when the discharge itself or the background conductivity eliminates the driving electric fields. The present formulation, contrary to [2], includes the contributions of the positive and negative ions, produced as a result of ionization and attachment, to the total electrical

current density and hence the evolution of the self-consistent fields. Because of their large densities at low altitude, the ion contribution to the net current is significant for slow discharges and in particular blue jet simulations. The electrostatic equations are solved in a different way, providing significant savings in computational time.

Polynomials are fit to the numerical results from detailed kinetic calculations [3] to obtain the primary electron energy, velocity, and production rate as a function of the total electric field (E) and the atmospheric pressure (p). At an altitude of about 55 km, the mean free path of the primary electrons becomes large. A simple prescription is used, for the first time, to allow the primary electrons to smoothly transition between the collision dominated regime and the free streaming limit.

The secondary (low energy) electrons produced in the avalanche process are collision dominated and establish equilibrium distributions in time scales much shorter than the time for runaway breakdown. Their mean properties are also defined by E and p and are derived from the standard swarm parameters [4,5].

3. Discussion and conclusion

We have been able to find reasonable parameters for intracloud and positive cloud-to-ground lightning strokes that produce the observables for red sprites, blue jets, and elves. Since we have just begun to explore the morphology of the observable emissions we do not claim that the cases we describe next are the only possible scenarios. The MCS, and the annihilation of charge by discharges in the MCS are modeled by the creation of charge of opposite polarity in free air. The highly complex thunderstorm complex is thereby eliminated, and we can only look at atmospheric evolution well above the discharge location. The charge is allowed to build with an

exponential time scale or with a constant current source (i.e. a linear time scale).

Four simulations that produced red sprites were initiated by a positive cloud to ground stroke. They discharged 200 C at an altitude of 11 km with an exponential time scale of 3, 5, 7, and 10 ms respectively. The computational grid extended from 20 to 80 km in altitude and 50 km in radius. The peak primary electron concentrations were 1.1, 0.75, 0.5, and 0.15 per cc respectively. In each case there were two large scale and very bright atmospheric discharges. However, when observed with a video camera and thereby integrated over 17 ms, to the observer there would only be one flash. For example, in the 7 ms case, the first discharge occurred between 6.7 and 8.0 ms after the start of the positive cloud-to-ground stroke. The second discharge occurred between 12 and 14 ms. The kinetic energy of the primary electron population in each discharge reached 100 kJ. The peak current to the ionosphere reached 6 kA.

In each of these four red sprite simulations, the electric field first broke threshold, for the runaway mechanism to start, at high altitude and the location for breaking threshold moved downward in time. By the time the threshold was broken at 30 km there were enough avalanche lengths traversed by the upward propagating electron beam to produce large concentrations responsible for the first discharge. This also had the effect of quickly shorting out the field in the region of the discharge. However, the external driving field was still growing around the high conductivity region eventually resulting in the second discharge. The external driving field was complete by this time and the runaway process was ended. The fastest case produced the highest peak primary electron concentrations and also the highest electric radiation fields - reaching nearly 40 V/m in the lower ionosphere. As a result this case also provides the electromagnetic environment required for elves.

For discharges that occur at lower altitudes within the MCS, more charge would have to be annihilated and conversely less charge for higher altitude discharges. The fact that the runaway mechanism produces red sprites with a wide range of time scales is a notable result. Red sprites are now observed quite routinely which suggests a

mechanism that is not too sensitive to normal lightning discharge parameters.

A blue jet was modeled with a constant current intracloud discharge of reverse polarity. Computationally this is simulated by the creation of a dipole. The location of the dipole was at 17 and 14 km. A current of 1 kA for 200 ms (or a total charge of 200 C) produced a blue jet that moved from the bottom of the grid (19 km) to 35 km with an average speed of about 70 km/s. In this case the electric field first breaks threshold near the cloud top and moves upward in time. The reverse polarity of the discharge means the primary electron beam is moving down. When the primary electron beam reaches 40 km in altitude the ambient electrical conductivity has had enough time to eliminate the driving electric field. Obviously the termination altitude is quite sensitive to the ambient conductivity profile. We have chosen a nighttime profile from [6]. The blue jet simulations are computationally more intensive because of their long time duration and because the avalanche process must still be resolved in space and with the same time resolution. Also, the peak electric fields during the evolution are less than a factor of two over the threshold value. Therefore the simulation is strongly dependent on the runaway process parameters near threshold electric field values.

We are continuing to explore the parameter space of the initiating lightning strokes and are also beginning to look at aspects of normal lightning in the context of the runaway mechanism.

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COMPUTER AND PHYSICAL SIMULATIONS OF ELECTRODISCHARGE PHENOMENA NEAR THE NEUTRON STARS

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1. Introduction

A principal new physical effects of current self-focusing (and defocusing) as well as the "shooting solitons" (SS)-generation were observed in our physical and computer experiments [1-3]. Based on considered nonlinear phenomena a new mechanism of charge particle generation from nucleus of quasi stellar radio sources (QSS), pulsars have been proposed in [3-5]. This paper deals with a continuation of our work in area of physical and computer simulations of electrodischarge processes near the neutron stars (NS). We consider a question of "working" pulsars (including X-ray pulsars) and represent a new interpretation of "strange" behavior of QSS 3C273. As well as in [6] we will regard that a source of super high power jet is a black hole. But in contrast with a considered there 4 models of jet generation, which are based on an assumption about giant mass of black holes (about of 10^{11} of sun mass M_{\odot}), our model is based on an Oppenheimer-Snyder's prediction that the mass of typical black hole (NS) is about of $3M_{\odot}$. For explanation of an anomalous light brightness and strong microwave radiation from 3C273 we took into account a possibilities of self-channeling of directed energy flows (including relativistic electron and ion jets, as well as an electromagnetic radiation). It occurs in result of density concentration in electric discharge induced plasma corona near the NS as well as in its magneto-sphere. Under this we regard that the represented in [6] estimations of extremely high ($10^7 M_{\odot}c^2$) energy of magnetic field and kinetic energy of particles is not correct. This estimation was produced for an increased volume of emitted sources and considers only a mechanism of synchrotron radiation without taking into account a possibility of formation of strongly directed energy flows, as well as possible radiation from beam plasma [7,8] and a reflection of electromagnetic waves of Space (with its amplitudes and frequencies multiplication) from the moving with relativistic velocity a large front of jet (see, for example, [9]). For our opinion the disregarding this important phenomena is not correct. For example also it is not correct to speak about extremely high temperatures of low intensity He-Ne-laser on the base of its extremely high brightens temperatures (which may be, for example, up to 10^{15} K under intensity 10 mW). By the way as it was notified in [10] the most of QSS can not be observed because of its jets generation occurs under big

angle to observer! Note also that earlier in [11] a physical simulation of astrophysical jet generation (in a case of an accretion disk) had been considered using laser plasma as well as 2-D MHD computer simulation on the base of the pinch effect at an uncontrived plasma configurations, in which an azimuthal field occurs. In contrast to [11] in our modeling the mentioned above nonlinear phenomena are very important. They appear in essentially strongly coupled plasma in micro volume of cathode torch or in macro volume of plasma corona of electrical discharges near NS. We emphasize that picosecond Nd-YAG laser in our physical simulation was used as "shoot trigger" and as a diagnostic instrument for visualization of jets produced due to electro-discharge nonlinear phenomena after a few nanosecond after ignition.

2. Electrohydrodynamic jets

For simplicity we disregarded a peculiarities of space-time near the NS calculations which was produced by Oppenheimer and Snyder, Zel'dovich and his group [6]. At the first approximation we also disregarded a magnetic field (remarkably that in computer experiments it was easy to "switch off" its influence). We used a 2D-mathematical model [12,13], which is based on the electrodynamics, hydrodynamic and heat-transfer equations. It is very important that thermal and electrical conductivity were calculated including effects of strongly coupled plasma. Now we represent some results of direct computer simulation of such exotic electrical discharge (see Fig.1 as well as an additional figures in [4]). We assumed that at the surface of NS there exist a thermoemission processes with an initial temperature in some spot (with a radius of 20 m) of the order of 20 eV and work function about of 200 eV [14]. The tension of electric fields near the surface of neutron stars may be 100 MV/cm in accordance with an estimations in [14]. In this simulation we proposed that the distance between the surface of neutron star crust (with a density of iron about of 10^5 g/cc) and its magnetosphere equals to 100 m as in [15]. In Fig 1,a spatial distribution of current density in plasma torch of such exotic discharge is represented. We can see, that in the vicinity of central region of plasma torch the self-focusing of electric current and volumetric generation of SS take place similar to laboratory plasma [1-5]. High density electron beams are generated (its density does not show in figure) and accelerated in strong electric fields up to relativistic energies. Due to rotation of NS the shooting

of jets occurs strongly in one direction like as from gyro-stabilized platforms due to the rotation of NS. By the way, the particle beams which generated during NS-storms can be a large lasers (free electron lasers - for generation an electromagnetic radiation as well as a free ion lasers - for gravitational radiation). The temporal behavior of the total current of such "electrical generator" was represented in [4]. In accordance with our calculations we can conclude that an intensity of relativistic electron beam riches a values of order of 10^{20} - 10^{22} W/cm² with a pulse duration of about 0.5-1 msec. These pulses can recurred with a cycle time of a few msec. It is obvious that during such electrical discharges the generation of high power electromagnetic radiation (including X-ray due to overheating instability in plasma corona [3,5]) take place. The main plasma parameters at some intermediate time are represented in Fig.1 b, c). Naturally we can see only fragment of plasma and jet formation in the calculation frame with $R \times Z = 80 \times 120$ m (in the depth $0 \leq Z \leq 20$ m from crust of NS. A strong shock wave (with $V_s \sim 10$ -20 km/s) is generated and a crater is formed A mass velocities of plasma corona is about of 3-150 km/s. In considered example we have only one jet. In reality during NS-storm a few jets like as in our physical simulations may be generated simultaneously. It had been demonstrated in experimental investigations of laser-induced discharges in vacuum [1-3], as well as of laser produced plasmas in air near the Al-target [16], which presents an additional interesting possibilities for astrophysical applications (for example, the production a large relativistic mirror for reflection and enhancement of electromagnetic radiation from ambient stars [9]). Finally note that 2-D -MHD simulation confirms this result and in comparison to an electrohydrodynamic simulation we have only an additional compression of current densities due to an influence of magnetic field [17].

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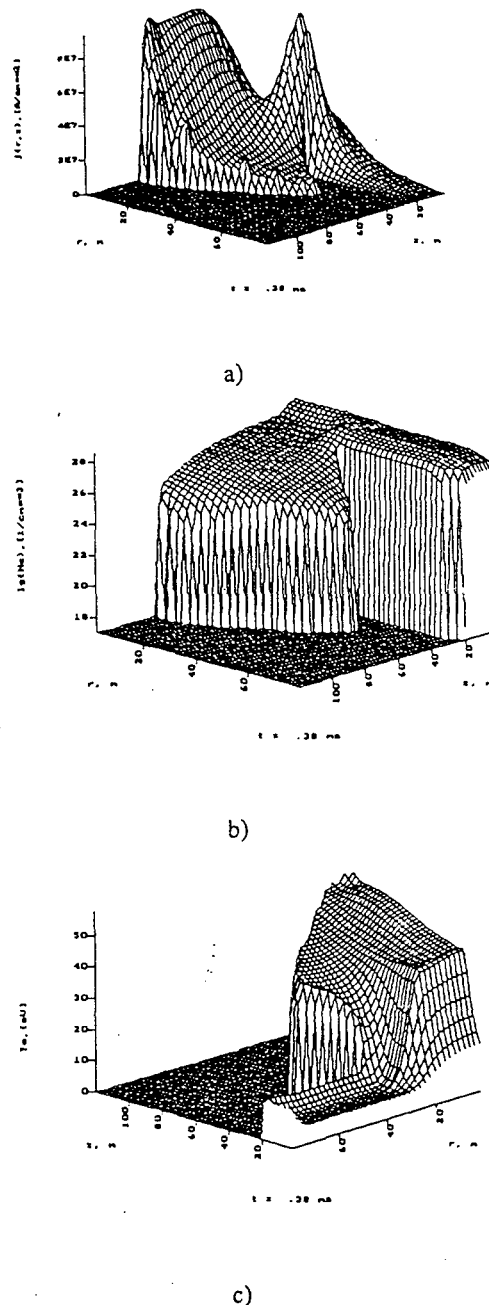


Fig.1. Spatial distribution of current density (a), plasma density (b) temperature (c) at $t=0.38$ ms in torch of NS.

Topic 16

Plasma sources of radiation.

Optimization of the radiative flux computation for high pressure discharges.

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1. Introduction

The energy balance of discharge lamps strongly depends on radiation, for this reason, the radiative flux is a fundamental quantity in radiation source research and development. Phenomena that generate radiation and formalism that ensues are well known for several decades⁽¹⁾ but the full calculation of the radiation flux density makes heavy demands on computer resources (see Eq.1). Hence, prohibitive time computation prompts the use of approximate methods^(2,3). In this paper, we propose a different method which enables to reduce strongly the time computation of the spectral flux density defined by the following four-fold integral

$$F_{\lambda}(r) = -4 \int_0^{\pi/2} \int_0^{\pi/2} \int_0^{\pi/2} \int_0^{\pi/2} \varepsilon_{\lambda}(s) \times \left\{ \int_0^{\pi/2} \sin(\Theta) \exp \left[-\int_0^s \kappa(\lambda, s') / \sin(\Theta) ds' \right] d\Theta_2 \right\} \cos(\Phi) ds_3 d\Phi_4 \quad (1^*)$$

for cylindrical and high-pressure discharges (assumed to be in local thermodynamic equilibrium⁽⁴⁾). Beside this, only energy transfers due to spectral lines will be treated.

It is shown that the application field can be characterized by a synthetic parameter called the equivalent optical depth (EOD) denoted τ_e and defined as

$$\tau_e = K_{Tc}(\lambda_0) R \quad (2)$$

where $K_{Tc}(\lambda_0)$ represents the absorption coefficient at the center of the discharge and at the center of the line whereas R is the radius.

This quantity, already used by Irons and Lowke^(3,5), gives an estimation of the maximum optical depth relative to the considered discharge in a very simple way. Furthermore, it enables to describe the application field of the code. It has been verified that the model can be used for values of τ_e lying between 10^{-5} and 10^{+10} . Moreover, these values probably do not constitute absolute limits. Such a large scope is some of interest in so far as it allows to consider resonance as well as non-resonance transitions.

2. The model.

The first part is concerned with the angular variations of the relative contributions of the planes within the framework defined in the introduction (integral n°4). This study presents a double interest. On the one hand, it

leads to a semi-empirical relation (see Eq.3) which allows to define an effective integration interval $\Delta\Phi_{\text{eff}}$.

$$\Delta\Phi_{\text{eff}} = \text{Arcsin} \left[\left(\frac{T_c - T_{\text{lim}}}{T_c - T_w} \right)^{1/h} \frac{1}{r/R} \right] \quad (3)$$

On the other hand, it brings forward the geometrical parameters which characterize a cylindrical discharge, the 'main plane' and the 'hot point' (see Fig.1). Concerning the radiative transfer along a plane (integral n°3), a reduced quantity called 'the efficient emission' is introduced in order to homogenize the results.

It is seen that this function (the efficient emission) passes through a maximum and may present strong gradients. Thus, it can be integrated more efficiently by adjusting the integration step around the maximum which will be in the first place approximated by a semi-empirical formula (see Eq.4a).

$$s_c(\Delta\lambda_r) = \frac{|r/R \cos(\Phi)|}{\left[1 - (r/R \sin(\Phi))^2 \right]^{1/2} - \cos(\Phi)} \times [1 - 0.0648 \ln(10\tau_e) \exp(-0.59\Delta\lambda_r)] \quad (4a)$$

Taking into account the variations of the efficient emission around this point, it becomes obvious that it is necessary to introduce a decreasing integration step within $[0; s_c(\Delta\lambda_r)]$ and an increasing one within $[s_c(\Delta\lambda_r); 1]$.

The introduction of these adaptative steps consists in characterizing at best the variations of the efficient emission by gaining time computation. In this way, the following formulae are introduced

$$1) s(n) = s_c(\Delta\lambda_r) (1 - 0.258^n) \text{ within } [0; s_c(\Delta\lambda_r)] \quad (4b)$$

$$2) s(n) = s_c(\Delta\lambda_r) (1 - n/10) \text{ within } [s_c(\Delta\lambda_r); 1] \quad (4c)$$

Afterwards, the calculation of the absorption factor (integral n°2) that occurs in the efficient emission expression is treated. This term is defined by a double integration.

As far as the integration of the absorption coefficient is concerned (integral n°1), the proposed approximation consists in integrating the absorption coefficient and the efficient emission (integral n°3) by using the same integration steps. From a numerical point of view, this approximation means that the spectral flux density can be treated as a three-fold integral although its expression is given by a four-fold integral.

* The successive integrals are numbered by the subscripts 1,2,3,4 which appear under the variables.

Concerning the second integration (integral n°2) which gives the absorption factor, the provided solution is the same as the one used for the planes in so far as it is based on a decrease of the interval which needs to be considered.

3. Results.

This section is devoted to a presentation of the spectral flux density relative to the main sodium and mercury lines. Firstly, a comparison with the results of Lowke⁽⁶⁾ concerning the D lines is given in order to validate the model (see Fig.2).

Secondly, results relative to a typical mercury discharge will be compared with a personal basic model due to the lack of references in literature. Taking into account the calculation hypothesis quoted in the introduction, this model exactly computes the equation (1) and uses precise integration methods given by the numerical library NAG⁽⁷⁾ (yielding the so called 'exact solutions').

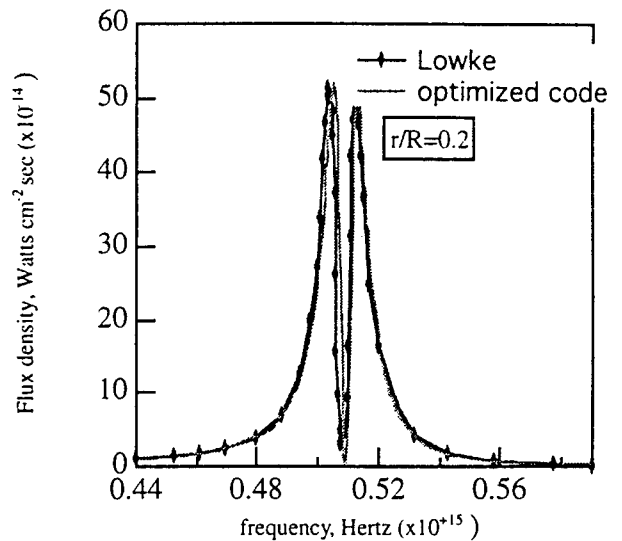


Fig.2. Comparison with the results of Lowke.

4. Conclusion.

The flux density which appears in the energy balance equation is defined by a five-fold integral. This quantity can be written as the integration over the wavelength (or the frequency) of the spectral flux density which has been especially studied in this paper.

This method is based on a physical analysis of the functions involved in the calculation. It turns out that a discharge can be described owing to a minimum number of spectral and geometrical characteristics. From these characteristics, the relative contribution of the planes and the efficient emission have been introduced in order to 'normalize' the behaviour of the discharge. The decrease of computation time is based on a localization of the effective contribution areas thanks to semi empirical formulae.

It is found that the numerical code predicts spectral flux density values which agree to better than 5% with 'exact solution' whereas time computation is more than two orders of magnitude less. Moreover, it can be used for EOD lying between 10^{-5} and 10^{+10} (for the typical cases that has been studied, τ_e varies from 10^{-1} to 10^{+4}). The next step of the computation procedure will consist in optimizing the integration of the spectral flux density in order to calculate the flux density.

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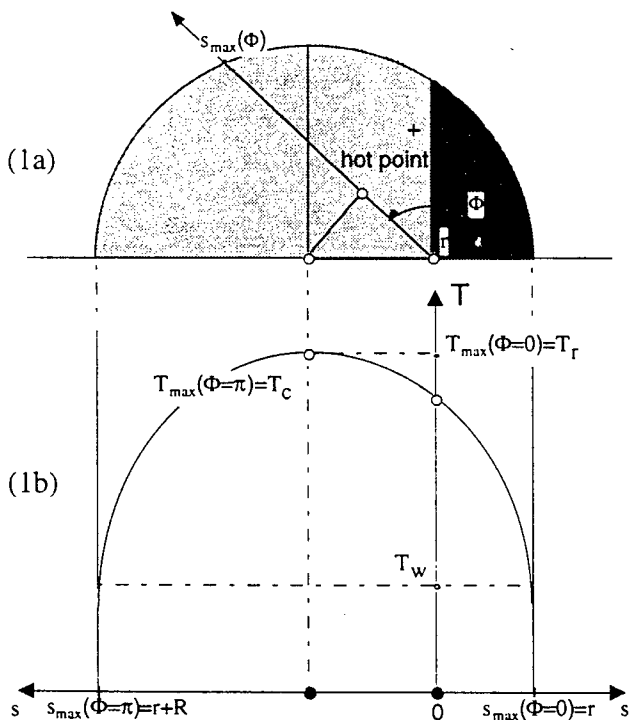


Fig.1a. Transverse cutaway of the discharge: position of the hot point within positive and negative areas. 1b. Justification from the temperature profile for planes corresponding to $\Phi=0$ and $\Phi=\pi$ ($\Phi=\pi$ represents the main plane).

Role of atomic oxygen in self-regeneration of CO₂ laser mixtures.

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1. Introduction.

The CO₂ decomposition due to collisions with electrons is responsible for mixture degradation and declining performance of CO₂ lasers. It has been shown in our previous papers [1-3] that atomic oxygen produced mainly in reactions with electronically excited N₂ molecules can substantially influence the level of CO₂ conversion described by so called "equilibrium CO₂ conversion, X_e". In this report we show that the atomic oxygen content influences the pressure dependence of X_e i.e. it can change its monotonous character into the one with a minimum.

2. Model Description

The model described in detail in ref. 1 is used here. The following plasma chemical processes of 54 species are considered: reactions initiated by electron collision, reactions of neutral atoms, molecules and their basic electron states, reactions with positive and negative ions, heterogeneous as well as homogeneous recombination and energy relaxation of electron levels.

The rate constants of reactions initiated by electron collision as a function of reduced electric field E/N and laser mixture composition were calculated, based on the electron energy distribution function (EEDF) and the relevant cross sections. In the Boltzmann equation, we took into account the processes of elastic collisions, electron excitation, ionization and dissociative attachment. Moreover, due to the importance of superelastic electron collisions, the effect of the CO₂ and N₂ vibrational excitation on EEDF was taken into account. The kinetic equations for chemical processes in a positive column of the DC plasma were solved under conditions of constant gas temperature, pressure and electron density.

3. Results and Discussion

Figure 1 presents the pressure dependencies of equilibrium CO₂ conversion X_e for different CO₂:N₂:He gas mixtures calculated for DC discharge chamber of MLT 1.2 kW laser [4] - solid lines. In contrast to these curves, the dashed line - representing equilibrium CO₂ conversion in small diameter discharge tube [5] - monotonously decreases to null with pressure growth. As discussed in our previous works [1,3] this is related to the role of ambipolar diffusion in this systems and the

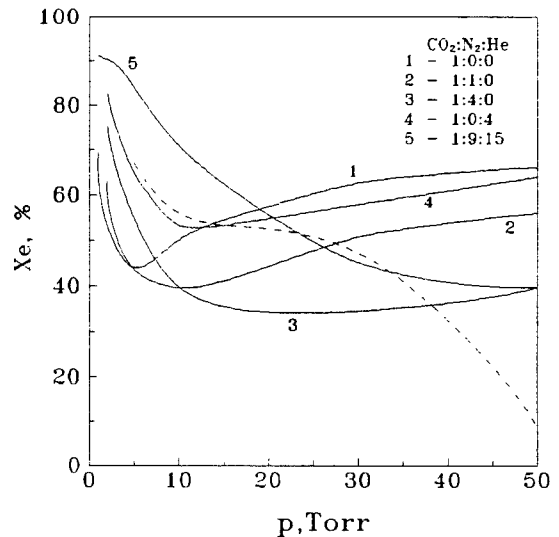


Fig. 1. Equilibrium CO₂ conversion as a function of pressure.

resulting pressure dependence of reduced field E/N. In large diameter discharge as in MLT 1200, pressure dependence of X_e can preserve monotonous character, e.g. curve (5) for the standard laser gas mixture CO₂:N₂:He = 1:9:15, but saturational plateau appears in this case. However, X_e(p) can change its monotonous character for the one with a minimum, which is most pronounced in the case of pure CO₂ gas discharge. As the dissociation rate (as well as E/N value) does not depend on the pressure discharge chambers, the character of X_e(p) is most probably determined by CO₂ reversion processes. In our previous works [1-3] already, we have reported that in MLT 1200 laser reversion takes place mainly in afterglow region and almost completely results from homogeneous and heterogeneous CO recombination on atomic oxygen i.e.



Therefore, Fig. 2 shows the relative recombination rates of atomic oxygen and equilibrium CO₂ conversion values (dashed lines) at the beginning of the afterglow region. Curve 1 represents the rate for these processes leading to CO₂ reversion, i.e. reactions (1) and (2), and curve 2 the rate of all the other processes. In the case of pure CO₂ gas

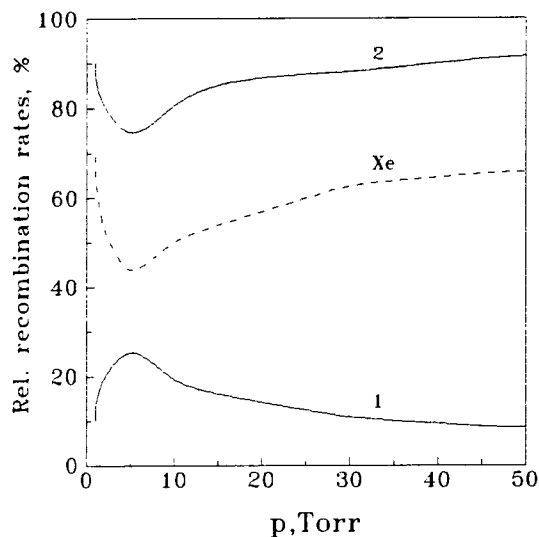
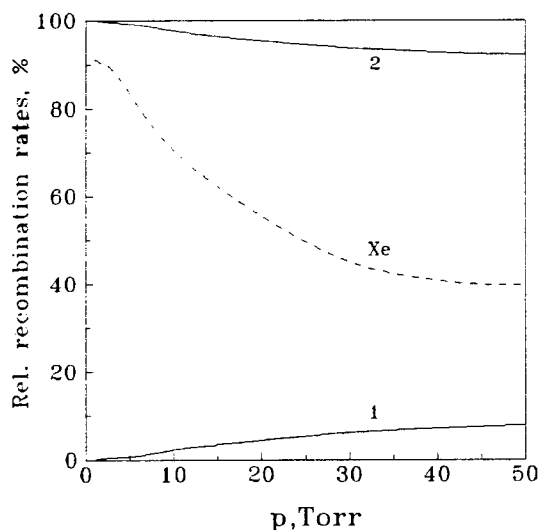
(a) discharge in pure CO₂ gas;(b) discharge in gas mixture CO₂:N₂:He = 1:9:15.

Fig. 2. Relative recombination rates of atomic oxygen as a function of pressure.

discharge (Fig.2.a), these processes are:
heterogeneous recombination of O on wall



in low pressure range and homogeneous recombination reactions



in high pressure region. In interim region, CO₂ reversion processes (1-2) reach their maximum

(curve 1) as the result of competition with reactions (3-6). This explains unmonotonous character of the $X_e(p)$ dependence.

When adding nitrogen to CO₂, the competition for CO₂ reversion processes increases by the presence of additional channels



in the low pressure range and besides,



is added in high pressure. However, nitrogen plays a positive role in CO₂ reversion process. As we see from curves 1-3 in Fig.1 the minimum of equilibrium conversion decreases, moves to higher pressure and widens up with N₂ content increase. It is related to the positive role of electronically excited nitrogen (especially N₂(A³Σ)) in production of atomic oxygen. In the case of the standard MLT 1200 laser gas mixture (Fig.2.b), reaction (7) and (3) significantly reduce the rates for CO₂ reversion in interim pressure range (no maximum of CO₂ reversion appears in this case (curve 1 in Fig.2.b). This determines the monotonous character of dependence $X_e(p)$ for CO₂:N₂:He = 1:9:15 mixture.

On the contrary, helium increases CO₂ conversion level as follows from comparison of curves 1, 3 and 4.

4. Conclusion

The pressure dependence of X_e can lose its monotonous character as we go from small diameter discharges to higher diameter one. It allows to find the pressure range where the laser mixture degradation will be minimal for given gas composition. The high content of nitrogen promotes the decrease of the mixture degradation but helium can intensify the CO₂ conversion.

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A Coupled Negative Glow-Thermionic Cathode Model for Low Pressure Fluorescent Lamp Discharge

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1. Introduction

The conventional fluorescent lamp is a low pressure mercury discharge with a buffer gas, typically argon, to maintain the charged particle balance. The life determining component of the lamp is the oxide coated thermionic cathode, so understanding its operation is of great interest within the lighting community. The basic parameters for the operating thermionic cathode and its interaction with the negative glow plasma have been described by J. Waymouth [1]. Briefly, the thermionically emitted electrons accelerate through the high field cathode fall region and undergo excitations and ionizations in the low field negative glow region. The negative glow plasma ions drift and diffuse back to the cathode, forming the cathode fall and providing the power to maintain cathode temperature. Although the basic theory and measurements of the important parameters such as cathode fall voltage, ratio of ion to electron current density at the cathode surface etc., are discussed in [1], only recently has a more quantitative ambipolar diffusion theory of hot-cathode negative glow discharge been developed [2]. The aim of this work is to couple both the cathode thermal model and the negative glow model so that all the important parameters such as the cathode spot temperature, cathode fall voltage, and negative glow discharge characteristics are calculated self-consistently for a wide range of parameters.

2. Details of the Model

The overall model is the synthesis of the following components: (1) negative glow model, (2) collisionless ion sheath model, (3) cathode emission and power balance models.

2.1 Negative Glow Model

The negative glow is assumed to be a quasineutral plasma governed by ambipolar diffusion equations for the electron and mercury ion (n_p). In addition, a third equation accounts for the relaxation of the fast electrons originating from the cathode (beam electrons, n_b):

$$\begin{aligned} \frac{d}{dx} [\mu_e (-\theta_e \frac{dn_p}{dx} - n_p E)] &= (1 + f_{ih}) v_h n_b - (\frac{D_a}{\Lambda^2} - v_{ip}) n_p \\ \frac{d}{dx} [\mu_i (-\theta_i \frac{dn_p}{dx} + n_p E)] &= f_{ih} v_h n_b - (\frac{D_a}{\Lambda^2} - v_{ip}) n_p \\ D_b \frac{d^2 n_b}{dx^2} + v_h n_b &= 0 \end{aligned}$$

The definitions for various quantities are given in Ref. [2]. For a given thermionic electron beam current and cathode fall, these equations determine the negative glow plasma density, the electric field distribution, and the ion current back to the cathode (based on the Bohm criteria).

2.2 Collisionless Ion Sheath Model

The beam electron space charge is neglected in comparison with the ion space charge in the Poisson Equation. No double sheath formation is considered. Assuming collisionless ions, the Langmuir sheath equations relating ion current density (J_i), cathode fall (V_k), and cathode fall thickness (d_k) are applicable:

$$\begin{aligned} E_k &= \frac{4}{3} \frac{V_k^{1/4} J_i^{1/2}}{(4\epsilon_0/9 \sqrt{M_i})^{1/2}} \\ d_k &= (\frac{4\epsilon_0}{9 \sqrt{M_i}})^{1/2} \frac{V_k^{3/4}}{J_i^{1/2}} \end{aligned}$$

where M_i is the ion mass. For a given J_i and V_k , the E_k and d_k are computed and E_k is in turn utilized by the cathode emission model.

2.3 Cathode Emission and Cathode Power Balance Models

For a given E_k and cathode temperature, T_k , the fully general thermal field emission model (Dyke and Dolan [3]) is implemented, including both the "evaporation" of electrons over the work function potential barrier lowered by E_k and the "quantum tunneling" of electrons due to "thinning" of the barrier. Such a model can be applied to cathode emission models for both low and high pressure discharges. For relatively low fields and low current density, the general formula for cathode emission reduces to the Richardson equation with the Schottky correction.

A simplified Cathode Power Balance equation is used, i.e. ion current power input is balanced by thermionic and radiative cooling:

$$I_i (V_k + U_i - \phi_w) = I_e \phi_w + \epsilon_m \sigma S T_k^4$$

where U_i , ϕ_w is the ionization potential and work function, and σ , ϵ_m , S and T_k are the Stefan-Boltzmann constant, thermal emissivity, surface area and temperature of the cathode spot respectively. A more

detailed cathode model including thermal conduction reveals that conduction power loss is small in comparison with thermionic and radiative cooling.

3 Results and Discussions

The basic variables are T_k , V_k and J_i , and the model is implemented as a set of nonlinear equations for the discharge current balance, ion current balance, and cathode power balance. The constant cathode spot area is an input parameter, and is assumed to be 0.02 cm^2 , based upon an experimentally observed value. Some important features of the parametric dependence are given below:

(1) As shown in Figure 1, V_k decreases and T_k increases with increasing current. Large increases in V_k are seen at low currents.

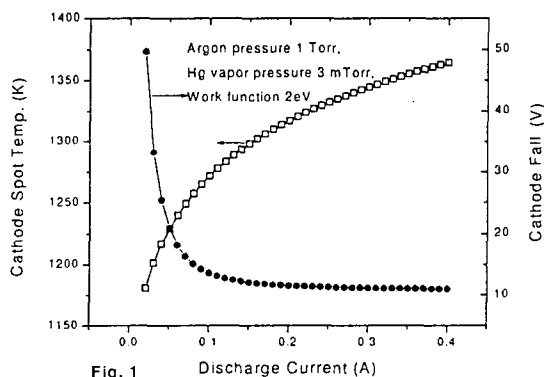


Fig. 1

(2) For a constant discharge current, I , V_k decreases slightly with increasing pressure as given in Figure 2. The effect of pressure on V_k is more pronounced for higher work functions.

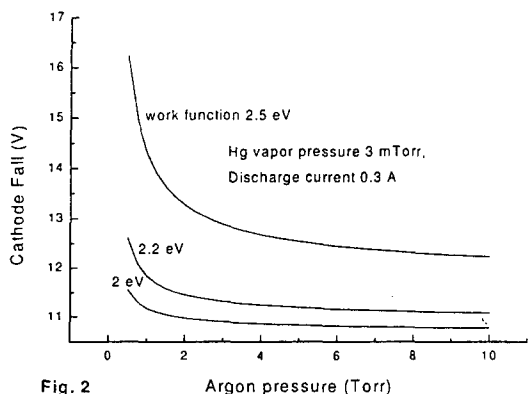


Fig. 2

Extensive measurements of the cathode fall using a Langmuir probe agree reasonably well with model predictions. Further details are given in [4].

(3) Non-monotonic variation of the ion current to electron current ratio at the cathode surface, J_i/J_e , with ϕ_w is shown in Figure 3.

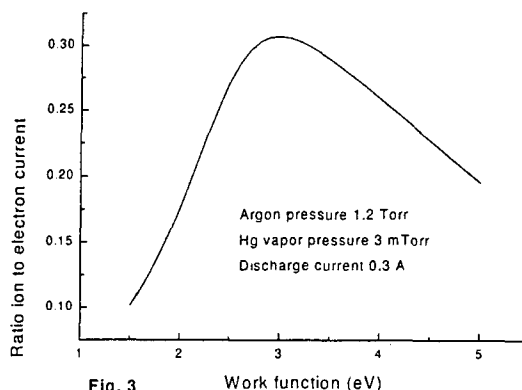


Fig. 3

The collisionless ion sheath is justified posteriori. With 1 Torr argon, d_k is 10^{-3} cm over a range of discharge current. The ion mean free path for Hg^+ is estimated to be $6 \cdot 10^{-3} \text{ cm}$. However, at sufficient high cathode fall voltage, excitation and ionization by electrons in the cathode sheath may be possible, and the non-ionizing Langmuir sheath equations are not valid.

Small increases in the hot spot area with increasing discharge current I_d were observed experimentally. This effect can be simulated by assuming the hot spot size varies as $S = 0.01 \cdot (1 + I_d/0.4)$. The result is given in Figure 4:

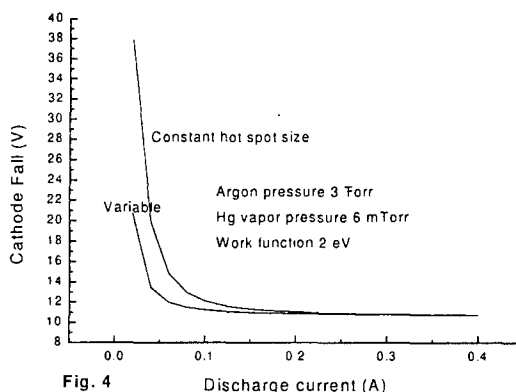


Fig. 4

To eliminate the assumption of constant hot spot size, the solution of a multidimensional cathode power balance with an appropriate negative glow plasma description is necessary. Some work in this direction has begun.

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Modeling and Diagnostics of Radiation Transport in High Pressure Discharges for Lighting

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Introduction

High pressure metal halide lamps are proving successful in providing high quality and efficient lighting for a number of applications. The gas discharges which provide the light source for these lamps are extremely complex systems, and the use of numerical models to assist in lamp development is limited by a lack of data for some fundamental processes. A particular example is radiation transport and the broadening of spectral lines.

Spectral line broadening plays two important roles in metal halide lamp operation. Firstly, the absorption in the wings of broadened lines is often different from that at the line centers, and this energy redistribution (radiation transport) can have a significant effect on the power balance of the lamp. Secondly, line broadening affects the spectrum emitted from the lamp and consequently the quality of the light source.

The major component of conventional metal halide lamps is mercury vapor at a pressure of several bar, the value depending on the lamp operating characteristics. The pressure of the dissociated metal vapors is typically 0.1 bar. Radiation and broadening of mercury lines can therefore be expected to make a significant contribution to the power balance of these lamps.

The classic experimental measurements for pressure broadening in high pressure mercury lamps are by Stormberg and Schäfer [1]. The inferred line broadening parameters differ in many cases by more than an order of magnitude from theoretical calculations. Further, the results relate to a particular set of discharge parameters and are based on assumptions regarding inter-atomic potentials which are themselves open to question. It has thus proved difficult to extrapolate the values obtained in [1] to discharge parameters relevant to other applications, such as metal halide lamps.

The purpose of the present paper is to quantitatively address differences between theory and experiment for high pressure discharges in mercury and to discuss the implications for numerical modeling of these discharges.

Theory

The principal mechanisms for broadening of spectral lines in high pressure metal halide lamps are van der Waals broadening and resonance broadening. Stark broadening can be important at high temperatures at the arc center and near the electrodes, but is not considered in the present discussion.

Van der Waals Broadening

Using the quasi-static approximation London [2] showed that the first order perturbation in an atomic energy level due to a perturbing atom vanishes unless both atoms are in identical states, and the second order term is [3]

$$\delta E_{mj}^{AB} = c_{6,mj} / R^6 \quad (1)$$

$$c_{6,mj} = \frac{3e^4 \hbar^4}{2(4\pi\epsilon_0 m_e)^2} \sum_{j' n'} \frac{f_{j'j}^A f_{nm'}^B}{\Delta E_{j'j}^A \Delta E_{m'm}^B (\Delta E_{j'j}^A + \Delta E_{m'm}^B)} \quad (2)$$

where δE_{mj}^{AB} Joule is the perturbation of the state m (energy E_m^A) of an atom of species A due to the presence of an atom of species B in state j . f_{jk}^X is the oscillator strength for transition $j \rightarrow k$ in species X , $\Delta E_{jk}^X = E_j^X - E_k^X$ and R is the inter-atomic distance.

The van der Waals broadening "half width" due to a local density of perturbers $N \text{ m}^{-3}$, expressed in wave numbers, is $\bar{w}_{mn}^v \text{ m}^{-1}$, where [4]

$$\bar{w}_{mn}^v = \frac{2\pi^2}{9c\hbar} \left| \sum (c_{6,mj} - c_{6,nj}) \right| N^2 \quad (3)$$

The quasi-static line profile for van der Waals broadening for the transition $m \rightarrow n$ about the line center $\bar{\nu}_{mn} \text{ m}^{-1}$ is [4]

$$\bar{L}_{mn}(\bar{\nu}) = \left(\frac{\bar{w}_{mn}^v}{\pi(\Delta\bar{\nu}_{mn})^3} \right)^{1/2} \exp(-\bar{w}_{mn}^v / \Delta\bar{\nu}_{mn}) \quad (4)$$

for $\Delta\bar{\nu}_{mn} > 0$ and $\bar{L}_{mn}(\bar{\nu}) = 0$ if $\Delta\bar{\nu}_{mn} < 0$, where $\Delta\bar{\nu}_{mn} = \bar{\nu}_{mn} - \bar{\nu}$, i.e. the line is only broadened on the "red" side and the maximum of the line profile is shifted by $\bar{\nu}_{mn}^v = 2\bar{w}_{mn}^v / 3$.

Resonance Broadening

Liebermann and Lowke [5] adapted the impact broadening theory of Griem [6] to include transitions from multiplet states. The resulting width for resonant transitions $m \rightarrow g$, $\bar{w}_{mg}^r \text{ m}^{-1}$ is

$$\bar{w}_{mg}^r = \frac{3r_e}{4\pi} \left(\frac{G_1}{G_M} \right)^{1/2} \left\langle \frac{f}{\Delta\nu} \right\rangle_M N \quad (5)$$

where r_e is the classical electron radius, G_M is the statistical weight of the multiplet M , G_1 is the statistical weight of the groundstate multiplet and

$$\left\langle \frac{f}{\Delta \bar{\nu}} \right\rangle_M = \frac{1}{G_1} \sum_{k,g} \frac{(2J_k + 1) f_{gk}}{\bar{\nu}_{kg}} \quad (6)$$

where the sum is over all groundstates g and all states k in multiplet M . The width of transitions $m \rightarrow n$, where m and/or n has a groundstate transition is

$$\bar{w}_{mn}^r = \max(\bar{w}_{mg}^r, \bar{w}_{ng}^r) \quad (7)$$

satisfying a Lorentzian profile

$$L_{mn}(\bar{\nu}) = \frac{1}{\pi \bar{w}_{mn}^r} \left(\frac{1}{(\Delta \bar{\nu}_{mn})^2 + 1} \right) \quad (8)$$

The line broadened profiles of spectral lines are thus a convolution of the profiles (4) and (8) [1].

Comparison with Experiment

We have previously reported [7] comparisons between experimental measurements of gas temperatures and spectral line broadening in mercury discharges and predictions using numerical models [8]. In the numerical programs, the gas temperature was determined self consistently by including a 1D model of the radiation transport in the energy balance equation. In the computations, the larger of the Stormberg [1] and theoretical values for the van der Waals broadening were used, while resonance broadening was computed by multiplying (5) by a factor 2/3 for agreement with the Stormberg [1] value for the 185 nm line.

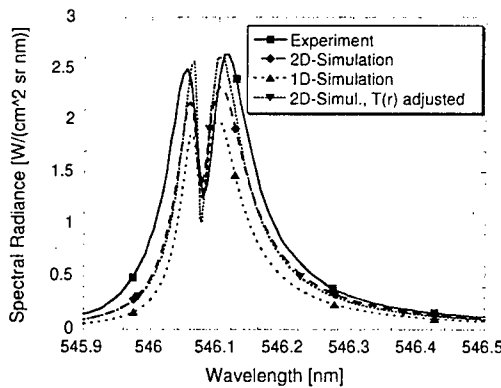


Figure 1: Comparison of theory and experiment for the Hg 546 nm line

Figure 1 shows a comparison between the experimentally observed line profile of the Hg 546 nm line with those computed using the temperature profile obtained from the 1D and 2D arc models. The discharge had a radius of 6.5 mm and a gas pressure of 3.5 bar. The measured gas temperature on axis was 6100 K and that computed was 5900 K.

The comparison between arc model results and experiment is poor. However, closer agreement was obtained by repeating the calculation using the experimentally measured temperature profile, suitably extrapolated in the outer mantle.

In pure Hg discharges, UV radiation at 185nm and 254 nm may represent 30% of the available radiation energy in the arc. Some of the discrepancy between experimentally observed and computed temperatures may be attributed to uncertainties in the profiles of these lines.

We are currently conducting a series of experiments in Hg discharges at pressures between 2 and 8 bar, in order to clarify some of the issues raised above.

Conclusions

The mechanisms for broadening of spectral lines in high pressure Hg lamps is still not well understood. A continuing experimental and theoretical research program is necessary if the radiation processes in metal halide lamps are to be well understood.

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Particules densites determination in high pressure mercury discharges

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1. Introduction

In high pressure mercury discharges or in metal halide discharges containing mercury as a buffer gas the profile of the 690.7 and 491.6 nm mercury lines (figure 1) is proposed to be used for electron and neutral densities determination, these two lines suffering no or little absorption: Particularly for the studied discharges, the transmission of the two lines is within 0.95-0.99. Because of this low absorption the shape of the line profile as emitted along a chord of the discharge is mainly due to broadening processes [1]. Therefore it can be expected that broadening of these lines would provide an easily used diagnostic tool. In this paper we report on the study of 690.7 and 491.6 nm mercury line broadening processes for diagnosis purposes.

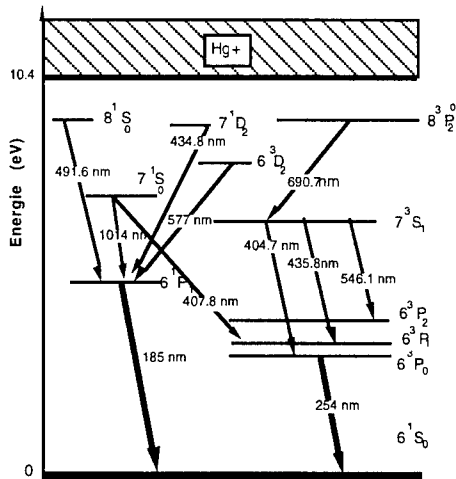


Figure 1: Energy levels in mercury

2- Line shape Modeling

Line profiles are computed by solving the integral form of the radiative transfer equation with the usual assumption of local thermodynamic equilibrium (L.T.E.). For local line profile we take into account Doppler

broadening and pressure broadening by neutral and charged particles. For this purpose we need plasma composition of the species which can be deduced from temperature profiles. Broadening constants are introduced as parameters which have been determined by comparing computed profiles with experimental ones.

We have estimate neutral and charged particles effects by performing time resolved measurements for several discharges operated on ac power. Computational details and fitted broadening constant values are given in our recents works [2], [3]. Broadening constante are resumed in table 1. With this set of values we find a good agreement between our computed and mesured profiles.

	491.6 nm line	690.7 nm line
$2\delta_n$	$2\delta_r (1 - B \cdot n_0)$	$2\delta_6$
Δ_n	$-0.13 \times 2\delta_r$	$\Delta_6 = 0.36 \times 2\delta_6$
$2\delta_{ei}$ and Δ_{ei}	Griem's formula	Griem's formula
rapport $2\delta_{ei}/\Delta_{ei}$	1.16	2.3
k_r	(2.7 ± 0.15) [2] 2.72 [4] 1.73 [5]	-----
C_4 (rad.cm ⁴ .s ⁻¹)	$1.8 \cdot 10^{-13}$ a	$3.5 \cdot 10^{-12}$
$A_{ea} \times 10^{-6}$ s ⁻¹	4.8	3.2
C_6 (rad. cm. ⁶ .s ⁻¹)	-----	$4.65 \cdot 10^{-29}$ a

Table 1: used formulas and broadening constantes

$2\delta_{ei}$, $2\delta_n$, $2\delta_r$, $2\delta_6$, are the full width at half-maximum for charged particles, neutral particles, resonance and van der waals

broadening respectively. Δ_{ei} and Δ_6 are the charged particles and van der Waals shift respectively. C_4 and C_6 are the broadening constant for Stark and van der Waals effect. B is a parameter and A_{ea} the transition probability.

3- Results

Due to the fact that the 690.7 nm and 491.6 nm lines profiles depend essentially on electron and neutral densities respectively, we expect that we can evaluate n_e and n_0 in L.T.E. conditions using iterative method. For practical use of the obtained results, we study the influence of the electron and neutral densities on the line broadening. We use a temperature profile whose analytic form is given by:

$$T(\rho) = T_c - (T_c - T_w) \rho^\beta \quad (1)$$

where ρ is the reduced radius, T_w the wall temperature ($T_w = 1000$ °K), T_c the axial temperature and β a parameter.

Results of figure 2 and 3 show that 2δ depends essentially on n_e and β for the red line and on n_0 for the blue one. Thus, by comparing experimental line widths with calculated ones we can estimate axial electron density n_e and evaluate axial neutral density n_0 value from the 690.7nm and 491.6nm line broadening respectively. With this two parameters one can characterize the discharge.

These curves lead to the following fitted analytical formula which gives 2δ as a function of n_e , β and n_0 :

$$2\delta_r(\text{nm}) = (-5.3 \cdot 10^{-3} + 8.7 \cdot 10^{-21} \cdot n_0) + (1.9 \cdot 10^{-17} + 0.3 \cdot 10^{-17} \cdot \beta - 3.1 \cdot 10^{-19} \cdot \beta^2) \cdot n_e \quad (2)$$

$$2\delta_b(\text{nm}) = -1.1 \cdot 10^{-40} \cdot n_0^2 + (0,374 - 5.3 \cdot 10^{-18} \cdot n_e + 1,12 \cdot 10^{-33} \cdot n_e^2) \times 10^{-19} \cdot n_0 \quad (3)$$

$2\delta_r$ and $2\delta_b$ are the FWHM of the 690.7nm and 491.6nm mercury lines respectively. n_e and n_0 are in cm^{-3} .

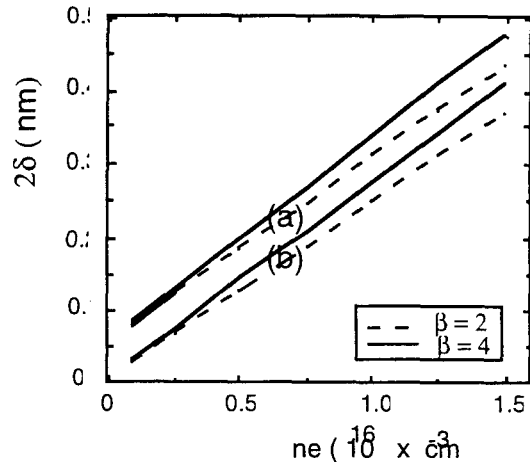


Figure 2: Calculated value of the 690.7 nm FWHM as a function of axial value of n_e and n_0 , with β as a parameter. (a): $n_0 = 7.3 \cdot 10^{18} \text{ cm}^{-3}$ and (b): $n_0 = 1.5 \cdot 10^{18} \text{ cm}^{-3}$

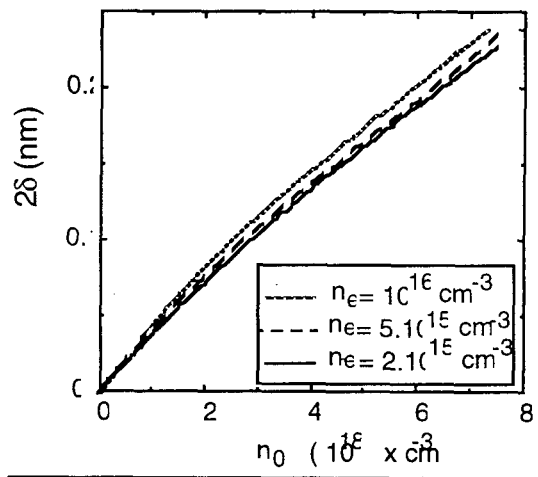


Figure 3: Calculated value of the 491.6 nm FWHM as a function of axial value of n_e and n_0 .

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VUV fluorescence of triatomic ionic excimers

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1. Introduction

Ionic excimer molecules have previously been investigated to extend the gas laser performances towards the shorter wavelengths. Particularly, experimental studies [1-3] allowed one to observe several VUV fluorescence lines of diatomic alkali (A) rare-gas (Rg) excimer from 63.8 nm (He^+K) [4] to 189.9 nm (Xe^+Li) [1]. Unfortunately, the strong photoabsorption by alkali atoms in the VUV region as well as some kinetic processes prevented the demonstration of such a VUV laser.

We report now the observation of alkali rare-gas triatomic ionic excimers, such as Rg_2^+A . We carried out experiments on Kr_2^+Cs (158 nm), Kr_2^+Rb (160nm), Xe_2^+Cs (190 nm), Ar_2^+Cs (135nm) by electron beam excitation of alkali rare-gas mixtures. The observation of the VUV emission spectra of these ionic molecules provided information about the electronic structure and the formation kinetic processes of these excimers.

2. Experimental setup

A cold cathode electron gun was used to excite transversally the gas mixtures [5]. This electron gun, energized by a 300 kV- 1500 J Marx generator (MX 31 from Physics International Company), is separated from the cell (active volume of $1.7 \times 1.7 \times 15 \text{ cm}^3$) by a 25 μm thick titanium foil. The current density was about 1 A/cm^2 for 800 ns. Under these conditions, an energy deposition of a few hundred $\mu\text{J}/\text{cm}^3$ has been produced in one bar of argon. In order to obtain sufficient alkali vapor density inside the cell one must heat the gas to 400°C.

The gas inside the cell is separated from the detection apparatus by a magnesium-fluoride window. The spectra emitted from the excited volume are observed with a 0.2 m Seya-Namioka vacuum ultraviolet monochromator (VM 502 Acton Research Corporation) with a 1200 lines/mm grating. The fluorescence emissions are either time integrated by an optical multichannel analyser (IVUV 700 Princeton Instruments) with a spectral resolution of 0.4 nm or time resolved by a fast solar-blind photomultiplier (Thorn Emi VUV C640).

3. Experimental results

Experiments were performed by electron-beam excitation of alkali rare-gas mixtures with and without argon as a buffer gas. Fig. 1 presents spectra observed

for three different argon/krypton/cesium mixtures. Before the introduction of cesium, the spectra recorded in the 120 nm - 180 nm region after the excitation of pure krypton or argon-krypton mixture consists only of the fluorescence of the broad second continuum of krypton (Kr_2^*) centred at 144 nm ($T \sim 350^\circ\text{C}$). In the presence of alkali vapor, the Kr_2^* signal intensity is greatly reduced and two other emission bands appear. As it is shown in Fig. 1, the spectra exhibit a narrow band (FWHM $\approx 1.5 \text{ nm}$) at 132 nm, the Kr_2^* emission, and a new broad continuum centred around 160 nm. The 132 nm emission has been extensively studied [6] and is generally attributed to the ionic excimer Kr^+Cs . The other emission, which appears only in the presence of cesium, and only for krypton pressure higher than 80 mbar, is attributed to the triatomic ionic excimer Kr_2^+Cs . As for the diatomic ionic excimer, this new transition will occur between the emitting state combining a Kr_2^+ ion and a Cs atom and the lower state Kr-KrCs^+ .

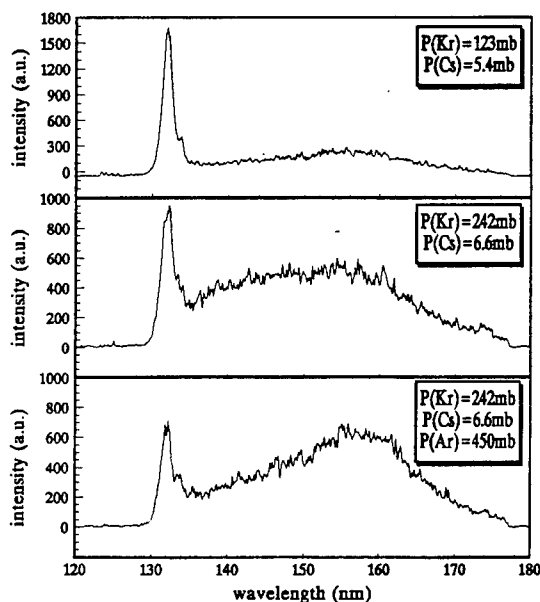


Figure 1. Emission spectra of Kr_2^* , Kr^+Cs and Kr_2^+Cs excimers at three different mixtures.

Figure 2 presents the emission spectra recorded between 120 nm and 180 nm when three different alkali rare-gas mixtures are excited by an electron beam. In figure 2.a (resp 2.b), one can observe an intense emission of Kr^+Rb at 134 nm (resp. Xe^+Cs at 160 nm) and a weak and broad emission at 160 nm (resp. 190 nm). This last

continuum is due to the radiative decay of the triatomic ionic excimer Kr_2^+Rb (resp. Xe_2^+Cs). Curve (A) of the figure 2.c was obtained by electron beam excitation of pure argon, and only the second continuum of argon Ar_2^* is visible (126 nm). Then, 6.6 mbarr of Cs has been added to this argon and the excitation of this mixture allowed one to record the spectrum of the curve (B). The Ar_2^* emission completely disappeared and a new broad continuum, due to Ar_2^+Cs , is now visible at 135 nm. The emission of the corresponding diatomic excimer Ar^+Cs , which emits at 114 nm, is not observable because of the absorption of the MgF_2 window.

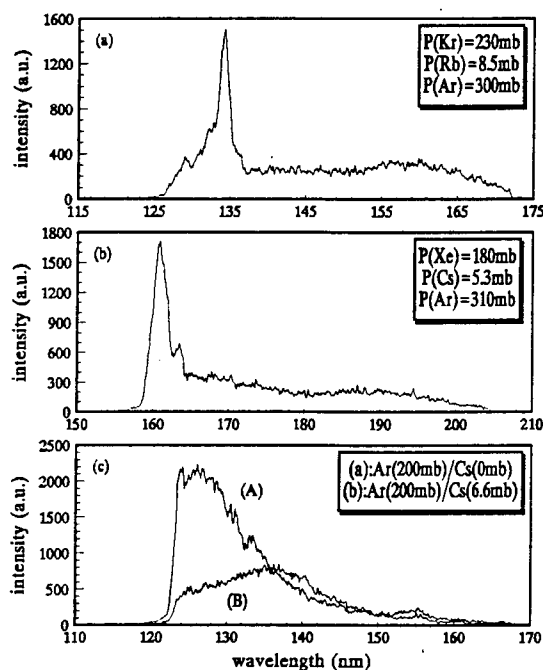


Figure 2 : emission spectra recorded between 120nm and 180nm after excitation of three different alkali rare-gas mixtures.

4. Discussion

4.1. Spectroscopy

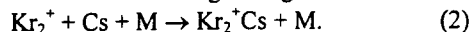
The Kr_2^+Cs continuum is centred at 159 nm with 16 nm width (FWHM). We estimated the energy E of the radiative transition as:

$$E = [I_p(Kr) - D_0(Kr_2^+Cs) - D_0(Kr_2^+)] - [I_p(Cs) - D_0(Kr^+Cs)] - \delta \quad (1)$$

where δ is the repulsive energy of the ground level and estimated to be 1 eV by comparison with Kr_2^+ excimer. The Kr_2^+Cs and Kr_2^+ molecules both exhibit the repulsive ground level leading to broad fluorescence emission spectra. The Kr_2^+ binding energy is 1.15eV [7], and thus, $D_0(Kr_2^+Cs)$ was estimated to be 0.9 eV, which is close to the value measured for the Kr^+Cs molecule (0.8 eV) [1]. In contrast to the alkali rare gas diatomic ionic excimers, the very broad, structureless character of the Kr_2^+Cs fluorescence spectra indicates repulsive behavior for the ground state.

4.2. Kinetics

We propose two channels for populating the upper fluorescence state of Kr_2^+Cs . By analogy with the Kr^+Cs kinetics, the first one is similar to the three body association processes clearly identified as the main production channel for forming the Rg^+A molecule



The second is a recombination of the diatomic ionic excimer with a krypton atom



From an analysis of the relative intensity ratios of the Kr_2^+Cs , Kr^+Cs and Kr_2^+ emissions as a function of the different gas pressures, we estimated the rate coefficients of the formation processes of this triatomic ionic excimer of $k_2 \approx 10^{-30} \text{ cm}^6/\text{s}$ for reaction (2) and $k_3 \approx 5.10^{-30} \text{ cm}^6/\text{s}$ for reaction (3).

5. Conclusion

The production of triatomic ionic excimers by electron beam excitation of alkali rare gas mixture was observed. The emission spectrum of Kr_2^+Cs is peaked at 159 nm and with 16 nm width. In spite of the high emission intensity obtained for the Kr_2^+Cs fluorescence, it is impossible to consider these molecules as suitable candidates for lasing because of a strong photoionization of alkalis in the VUV region and the competitive processes of the formation reactions.

The authors like to thank the French DRET for the financial support of this work.

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Hollow Cathode Effects in a Pulsed Capillary Discharge

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1. Introduction

The capillary discharge (CD) is known as a high brightness source in the VUV and soft X-ray region¹, which is also a suitable medium for discharge based X-ray laser studies². The successful operation of a CD as a high temperature plasma radiation source depends strongly on the initial formation of a conducting plasma column away from the wall. In this paper we report on time resolved studies of a fast CD which operates in the nanosecond regime with current in the kA region into a sub-millimetre diameter capillary. We present experimental evidence which indicates that electric breakdown inside the capillary is assisted by the hollow cathode effect (HCE)³. This is inferred from time resolved observations of axial electron beams, which are time correlated with measurements of discharge current and voltage, together with visible and VUV light emission. Time resolved XUV spectroscopic observations of the pulsed capillary discharge are presented in a companion paper⁴.

2. Experimental Apparatus.

The discharge chamber is arranged on the axis of a pair of parallel plate electrodes, separated by a thin dielectric to form a local energy storage capacitor which is pulse charged throughout a primary capacitor using a triggered switch. A pair of 90 mm diameter brass electrodes form the anode and cathode of the discharge, as well as the parallel plate capacitor. An alumina capillary, 0.8 mm diameter, 15 mm long, is located on axis between the two electrodes. On the cathode side, an additional plate is used to provide the optimum geometry of the aperture for the operation of the transient hollow cathode assisted ionization. A primary DC charged capacitor of 5 nF is used to pulse charge the storage capacitor within 100 ns. At a charging voltage of 25 kV, current above 10 kA is produced through the capillary, with a 10-90% current rise time of below 5 ns. The discharge is triggered by means of an auxiliary discharge from a small cable plasma gun, located a few mm behind the cathode aperture, with a delay of 80 to 120 ns. The cathode region is pumped through the capillary, thus allowing a higher pressure in the hollow cathode region, while maintaining a lower pressure in the capillary. The experiments have been performed in Argon at pressures

between 100 and 300 mTorr in the hollow cathode region (HCR) and a few mTorr at the Anode region. Apart from the voltage and current measurements, the plasma emission is studied in the visible with PIN diodes and photomultipliers, in the VUV region with filtered PIN diodes and XRD. Electron beams are measured using a Faraday cup and a scintillator-photomultiplier assembly.

3. Experimental Results

Figure 1 shows characteristic single shot signals for a triggered discharge at 12 kV, 160 mTorr. A cable delay of 110 ns is used for the auxiliary triggering discharge. The voltage rises to its maximum value in around 100 ns, and collapses in less than 10 ns at breakdown. At voltage collapse, a fast current pulse is observed, which is time correlated with an electron beam pulse. After the initial current pulse, the voltage recovers and grows up to ~1 kV. Additional electron beam pulses after breakdown are driven by the residual high voltage. The visible light emission is monitored axially, from behind the cathode. The first step observed in the visible corresponds to the auxiliary discharge. The second step coincides with the onset of the main discharge across the capillary. At later times the visible emission follows the oscillation of the external discharge current, through the primary circuit, as inferred from a software integration of dI/dt . The main feature of the triggered discharge are highly reproducible over the pressure range investigated. Figure 2 shows characteristic signals for a self breakdown, untriggered discharge, at the same conditions than in Fig. 1. When compared with the triggered discharge, the characteristic delay to breakdown in this particular shot increases by around 500 ns. An initial low current electron beam pulse is observed prior to electric breakdown. A fast current pulse is also observed at voltage collapse, which again coincides with the fast rise in visible light emission. At both triggering conditions, XRD and PIN diode observations show an initial fast, less than 10 ns width, VUV pulse which coincides with the main discharge current pulse. A high energy component, above 5 keV, in the electron beams has not been detected, presumably due to the relatively low applied voltage. The positive excursion in the electron beam signals is probably due to discharge plasma reaching the Faraday

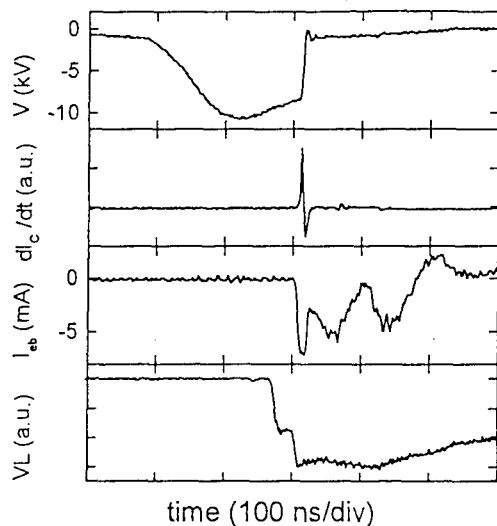


Figure 1: from top to bottom, applied voltage, time derivative of discharge current, electron beam current, and visible light emission for a triggered discharge.

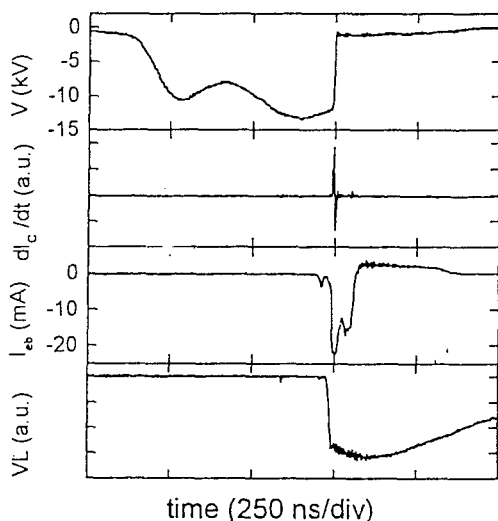


Figure 2: same signals as in figure 1 for an untriggered discharge.

cup collector plate. In general, the time delay to breakdown is not reproducible in the untriggered discharge, and an appreciable jitter is observed

4. Discussion

Transient hollow cathode discharges (THCD) are characterized by a rapid voltage collapse accompanied by the growth of an intense electron beam leading to the formation of an on-axis ionization channel, which develops throughout a moving virtual anode⁵. The electron beams originate in a plasma region inside the hollow cathode region, which develops spontaneously following the application of the high voltage across the

electrodes. Initially the electron beams are of high energy, of the order of the external potential, and low characteristic current. At later times, just before electric breakdown, the electron beams are of lower energy but much higher current. Apart from the high energy component, these features are clearly identified in the sequence of events leading to electric breakdown in the pulsed capillary discharge. Auxiliary triggering inside the HCR provides an additional source of plasma to enhance the electron beam emission. A single electron beam pulse is observed to start just before electric breakdown and fall after breakdown has completed. The trigger plasma also continues to supply electrons for extraction and is seen as the long duration e-beam signal detected after breakdown. This is quite different from the conventional THCD development. In the late case, the formation of the electron beam relies purely on self sustained ionization processes inside the HCR, and the two periods observed, before and at the time of electric breakdown, are characteristic of a self breakdown THCD operating on a much lower aspect ratio⁶. The partial voltage recovery after the fast current pulse is a good indication that the initial discharge channel has been initiated along the capillary axis, away from the wall. Expansion of the plasma channel results in material being ablated from the capillary wall, thus leading to a fast cooling, with a subsequent increase in plasma resistivity.

5. Conclusion

Our results show that the HCE is present in hollow cathode discharge geometries with a much higher aspect ratio than those previously investigated⁶. The pulsed capillary discharge can be initiated successfully with the assistance of the hollow cathode effect. The resulting discharge is characterized by a short, less than 5 ns half width current pulse, with an associated XUV light pulse⁴. The enhanced HCE due to the auxiliary discharge allows the XUV light pulse to be synchronized to external events.

6. Acknowledgments

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High energy photons emitted from a high voltage fast discharge in vacuum and in low pressure gases

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1. Introduction

Pulsed electrical discharge in vacuum are currently founding an increasing number of applications in various field concerning both research and industry, including vacuum switches, circuit breakers, high power X-ray sources, etc...

In this work we report on the production and the analysis of the high energy photon emission from high voltage fast discharge in vacuum and in low pressure gases.

2. Experimental set-up

The experimental set-up is shown in Figure 1. The discharge cell made of quartz has a cylindrical shape (3 mm wall thickness, 35 mm outside diameter, and 130 mm length) on the axis of which are placed a hollow-cathode and a sharp anode. Experiments with different electrode material and geometry were performed. The results presented here were obtained with a 8 mm Cu hollow-cathode and 8 mm diameter W rod with 60° conical shaped tip.

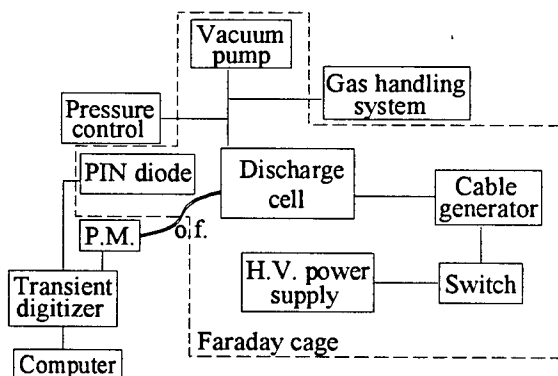


Figure 1: Block diagram of the experimental set-up (o.f. = optical fiber).

The high voltage pulses were delivered by a cable transformer which is powered by ceramic capacitors disposed in a Blumlein-like configuration and switched by a dielectric barrier discharge (DBD) triggered spark gap. Open circuit peak voltage in excess of 400 kV in typically 60 ns duration (FWHM) can be achieved while commutation occur at low voltage (< 20 kV). The maximum electrical energy stored in the system was about 7.2 J.

Extensive measurements have been made to study the characteristics of the emission of the radiation as a function of a wide range of experimental conditions (nature of gas, pressure, charging voltage, electrode material and shape, electrode gap) and the discharge was characterized by both electrical and spectroscopic means.

3. Results

When breakdown occurs, the radiation emitted from the plasma cover the large spectral band extended from the visible to hard X-rays.

Figure 2 shows the dependence of the X-ray dose per pulse and the duration in time (fwhm) of the output pulse, respectively, as functions of the residual air pressure in the discharge cell. The X-ray emission appears below threshold pressure (TP) of about 0.4 mbar for most of electrode spacings having some practical utility. Below the characteristic pressure (CP) of about 0.05 mbar, the X-ray production efficiency is high and the X-ray output remains constant exhibiting a *plateau*. The X-ray pulse duration exhibits the same behavior as the X-ray dose versus the residual pressure.

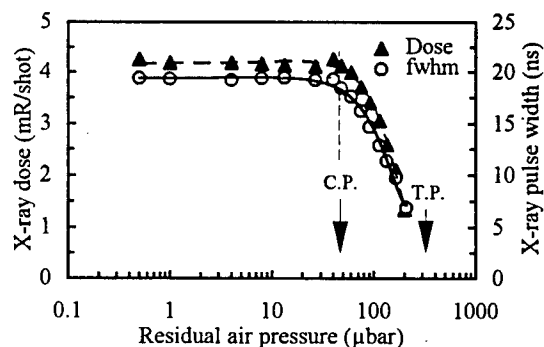


Figure 2: Effect of the residual pressure in the discharge cell on the X-ray dose per shot and on the X-ray pulse width measured at 25 cm from the source. (C.P. and T.P. represent the characteristic and the threshold pressures respectively).

These results indicates, that in such experimental conditions a high vacuum is not necessary as indicated in previous studies [1, 2]. One can note that when the residual pressure varies from 0.4 mbar to 0.05 mbar, the duration (fwhm) of the X-ray emission increases by nearly one order of magnitude. This behavior gives the possibility to adjust the pulse length from 4 ns to 20 ns

but at the expense of the emitted dose for the shorter pulse durations. This makes this high energy photon source applicable to specific fields of research such as, for example, photo-excitation of gaseous matter [3] and observation of ultra-short phenomena.

Discharge operation is also possible in gases (He, Ne, Ar, Kr, Xe, H₂, N₂) at pressures varying from 10⁻³ mbar for xenon to about 1 mbar for helium without changing the emitted dose. In these cases the characteristic pressure (CP) seems strongly correlated to the ionization potential of the considered gases. The higher values of ionization potential correspond to the higher CP's except in the case of hydrogen [4].

A typical record of the X-ray power output in the forward direction as a function of time is shown in figure 3 for one of the lowest pressure of figure 2.

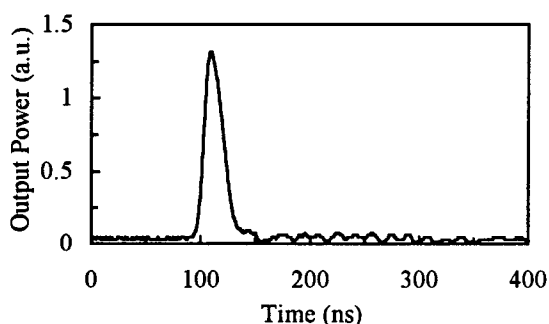


Figure 3: Typical recording of the X-ray output power as a function of time in the case of 15 kV charging voltage.

The spectral distribution emitted by the high flux X-ray source was estimated from attenuation measurements with foils of known thickness. X-rays of energy up to 400 keV can be generated and detected through a mylar window which limit the detection of the low energy part of the spectrum to around 5 keV.

An example of experimental data obtained in the case of the use of aluminum foils is shown in figure 4. These results are compared to the results of the theoretical simulation including the fact that the X-ray emission is polychromatic. In that case, the absorption cross section $\sigma(E)$ strongly depends on the incident photon energy E . The fraction of the transmitted intensity, integrated all over the energy spectrum (from E_1 to E_2), is related to incident intensity $I(E)$ by the following relation:

$$T = \frac{\int_{E_1}^{E_2} I(E) \exp(-\sigma(E) n x) dE}{\int_{E_1}^{E_2} I(E) dE}$$

where n , and x represents the absorber density, and the absorber thickness, respectively.

Comparison between experimental and theoretical data shows that around 90% of the total X-ray energy is radiated in characteristic lines of the anode material (K and L lines). The 10% remaining are distributed over a large bremsstrahlung continuum with an endpoint energy corresponding to the voltage across the electrodes.

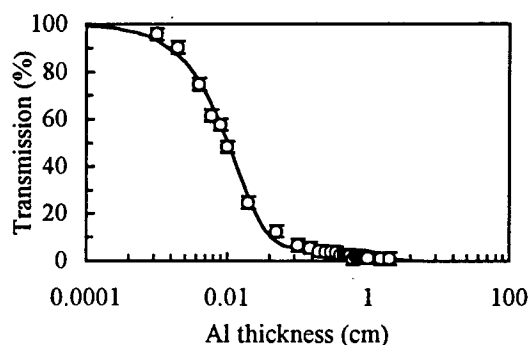


Figure 4: Experimental (dots) and calculated (line) transmission through different Al thickness. (Charging voltage = 14 kV, Anode W and cathode Cu).

The endpoint energy of the spectrum was confirmed by using SILENA detector calibrated by ¹³²Cs radioactive source coupled to a multi-canal analyzer. At 14 kV charging voltage the continuum spectrum has a maximum intensity at about 50 keV. In this case, and for 1 R ($1R = 2.58 \times 10^{-4} C/Kg$) X-ray dose, the number of photon integrated all over the spectrum was about 4×10^{12} per shot.

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From the "third continuum" to the "molecular ion continua" of rare gases

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1. Introduction

Over the past decades, the fluorescence of rare gases (Rg) in the UV-VUV domain has been the subject of a large number of publications. Two major points have to be particularly enlightened: first the use of a great variety of excitation means: synchrotron, alpha particles, electron beams, charged particle beams, dielectric barrier discharges, X-rays,... and second the diversity of excited media: Rg at pressures between a few mbars up to several tens of bars, gas jets, clusters, solid targets,...

Besides the well known first and second continua of Rg_2 , arising from transitions of the two lowest excited states of the neutral dimer (Rg_2)^{*} to the repulsive ground state, another broad spectral feature has been reported for all Rg at higher wavelengths than these two first continua. This emission was labelled as the "third continuum" [1] of Rg in the continuation of the denomination of the two first continua. Interest in this fluorescence relies both in the determination of the species at its origin and in the possibility to develop new efficient or even coherent UV-VUV sources. The manifold of experimental and theoretical works dedicated to the "third continua" of Rg has unfortunately led to a rather controversial situation concerning the origin of the fluorescence except for the ionic and molecular character of the emission.

In the course of this research, the flash X-ray excitation of both pure and binary mixtures of Rg at pressures ranging from a few mbars up to 30 bars allowed us to constitute the more complete database on the fluorescence of Rg. The possibility to study the Rg fluorescence with a single excitation source on a large pressure domain and especially with the availability of time resolved spectroscopy from 110 nm up to 800 nm enables us to produce almost all the spectra published in the literature for about thirty years.

This detailed spectroscopic study of Rg fluorescence leads us to propose a new and more adapted denomination of the so-called "third continuum". We showed that "third continuum" is composed of different spectral components with different origins [2], as also suggested by Langhoff [3]. The denomination "molecular ion continua" appears more precise to clearly describe the whole fluorescence emitted by the Rg on the UV-VUV domain.

In the following, argon will be chosen as an archetypical case of Rg as regard to the particularly pronounced evolution of the shape of its fluorescence spectra with pressure or versus time after pulse excitation. Then, the peculiar interest of the flash X-

ray excitation for kinetic studies of excitation transfer mechanisms or heteronuclear ion production, both at very high pressures, will be presented.

2. Results and discussion

The deposition of large doses, about one rad, of X-ray photons with energy of about 8 keV in Rg induces intense fluorescence on the UV-VUV domain. The X-ray doses were delivered by a home developed powerful flash X-ray facility able to produce X-ray pulses, with typical fwhm of 20 ns, at high repetition rate, up to 50 Hz and with an exceptional time stability for period of hours. The fluorescence was detected and analysed with fast photomultiplier tubes and a fast digitizer (with an overall time resolution of about 2 ns).

For argon, krypton and xenon the fluorescence of both second and "third" continua were efficiently produced. In the case of argon, five different spectral components, respectively centered around 160, 185, 200, 225 and 245 nm, were evidenced as depicted by the figure 1. These five spectral features are proposed to be labelled as third, fourth, fifth, sixth and seventh continua of argon. Figure 1a) presents the time integrated spectrum of argon fluorescence at a pressure of 0.5 bar. For this pressure, the third and fifth continuum can be clearly seen. For higher pressures, e.g. 17 bars, the figure 1b) exhibits the fourth, sixth and seventh continuum fluorescence of argon over the fifth continuum.

The apparition of these five continua depends on the pressure as shown in figure 1. At a given pressure, for which all of these continua are emitted, i.e. above atmospheric pressure in our experimental conditions, it has been shown that these continua does not appear at the same time in the plasma relaxation. These two features, dependence versus pressure and versus time, enable to understand the problem encountered by authors working on restricted range of experimental parameters (cw excitation, small pressure range,...). Another particularity of these Rg continua relies in their relative large broadness. The fifth continuum presents a spectral fwhm of about 50 nm while all the others have spectral fwhm of about 20 nm. This induces a strong overlap of these different continua and consequently the difficulty in their detailed analysis.

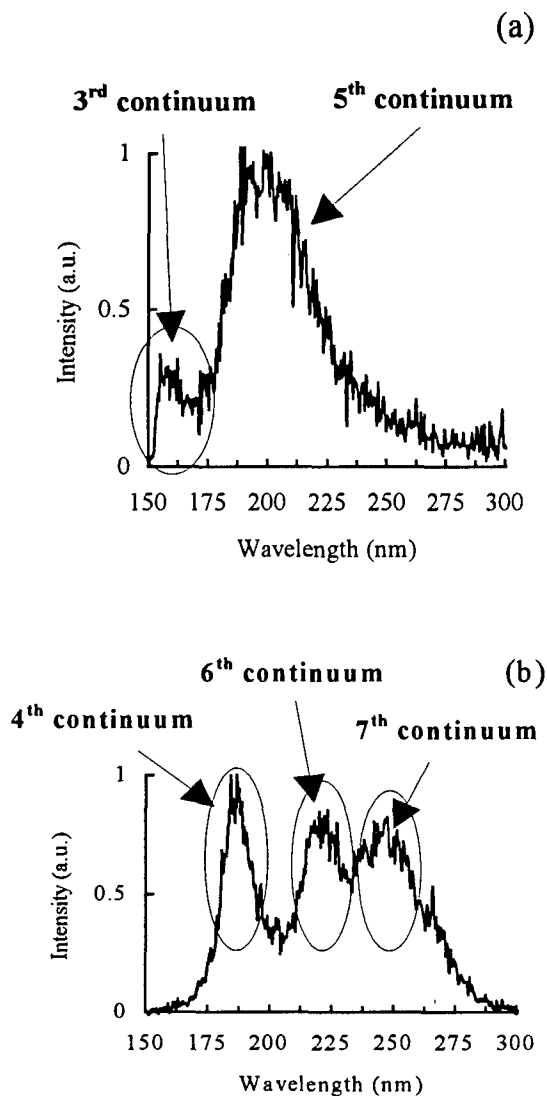


Figure 1: Time integrated spectra of the fluorescence spectrum of argon excited by a flash X-ray source at: (a) 0.5 bar and (b) 17 bars.

The existence of five different continua of argon between 150 nm and 300 nm was confirmed by gas mixtures fluorescence study. The figure 2 presents the time integrated spectrum of a mixture (Ar:N₂/100:1) at a pressure of 5 bars. Two main results were deduced from this spectrum. First, nitrogen was shown to be an efficient quencher of the 4th, 6th and 7th continua of argon while having less effect on the 3rd and 5th. The spectra of the mixture of argon with nitrogen at high pressure, e.g. 5 bars see figure 2, appears quite similar with that of pure argon for low pressure (below atmospheric pressure). Intense production of the fluorescence of the second positive system of nitrogen, N₂⁺(C) states, were measured at 298, 316, 337 and

380 nm. The rate coefficient for the reaction of argon metastable levels, Ar⁺(4s), with N₂ has been measured on the whole pressure domain ranging up to 30 bars.

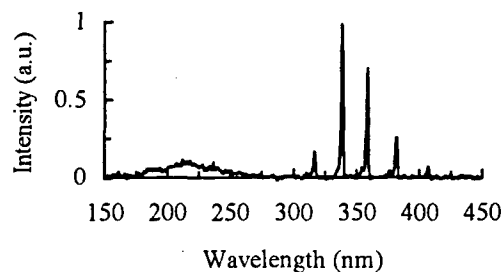


Figure 2: Time integrated spectrum of a mixture of argon and nitrogen (Ar:N₂/100:1) at a pressure of 5 bars excited by flash X-ray source.

The flash X-ray excitation of binary mixtures also leads to the production of heteronuclear ions, (ArNe⁺) at 216, 224 nm and (Ar⁺Xe) at 328, 509 nm. In this case, flash X-ray excitation appeared as a unique source to study these fluorescences both for pressures for which, to our knowledge, they have not been reported, and especially with time resolved spectroscopy. For argon-neon mixtures, long-lived emission was measured. For example, at a pressure of 1.3 bar in the mixture (Ar:Ne/100:0.7), the 216 nm and 224 nm fluorescence signal exhibits a time fwhm of about 100 ns. The fluorescence of (ArNe⁺) originates from a transition between ArNe⁺ and Ar⁺Ne ions. Thus, the long-lived fluorescence of this ionic species indicates the presence of long-lived high energy levels in our experimental conditions.

3. Conclusion

The whole fluorescence emitted by argon from 150 nm to 300 nm was shown to be the result of the superposition of five different continua labelled as 3rd, 4th, 5th, 6th and 7th centered respectively around 160, 185, 200, 220 and 245 nm. Same denomination appeared unavoidable for krypton and xenon. The possibility to study heteronuclear ion fluorescence and excitation transfer mechanisms at high pressure (up to 30 bars) with flash X-ray excitation was demonstrated.

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Temporal and Radial Behaviour of the Metastable Density in a Pulsed Xenon Discharge at Medium Pressure

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1. Introduction

The temporal evolution of the rare-gas plasma at medium pressure is controlled by the interplay of various electron and heavy particle collision processes. For the understanding of the discharge plasma the population of the metastable $1s_5$ level of the rare-gas atoms is of great interest. These excited atoms play an important role for the electrical behaviour and are precursors for the first and second excimer continuum radiation. In this paper experimental and theoretical results obtained for the constricted positive column plasma of a pulsed xenon discharge are presented.

2. Experimental Set-up

The absolute densities of the metastable xenon atoms have been determined by the hook method, which was introduced first by Rozhdestvenski in 1912 [1]. This classical interferometrical method uses the anomalous dispersion in the vicinity of an absorption line, where rapid changes of the index of refraction occur. The experimental set-up is shown in Fig. 1.

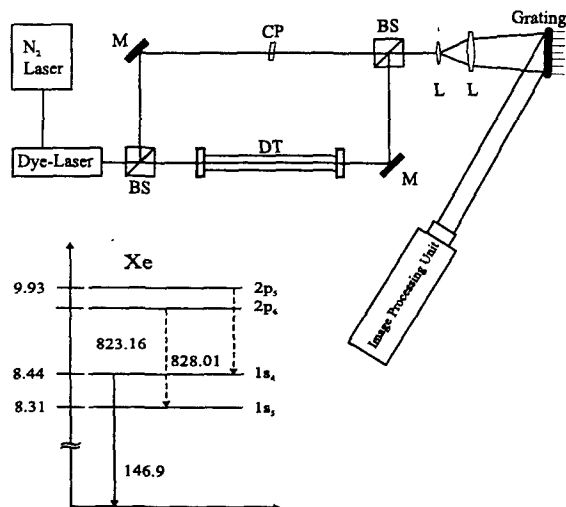


Fig. 1: Hook method. BS: beam splitter, CP: compensating plates, DT: discharge tube, L: lens, M: mirror.

A Mach-Zehnder interferometer has been used to measure the wavelength distance Δ between the minimum and maximum in the interference pattern. The background light source is a dye laser with

a beam diameter of 0.3 mm. This laser has been pumped by a N_2 pulse laser with a pulse duration of about 10 ns. Instead of a conventional spectrometer a combination of a beam expander, a grating with 1200 lines/mm and a CCD camera has been employed. The interference patterns are stored and analysed by a PC. For the analysis the hook vernier method has been used [2].

The density N of the lower xenon level of the transition $2p_6-1s_5$ at the wavelength $\lambda_0 = 823.16$ nm is given by

$$N = \frac{\pi K \Delta^2}{r_0 f l \lambda_0^3} \quad (1)$$

Here K , r_0 , f and l are the hook constant as determined from an undistorted fringe pattern, the classical electron radius, the oscillator strength of the transition and the absorption length, i.e. in this case the length of the positive column plasma. A special gate circuit allows to measure the particle density at any time of the discharge period. The measurements have been performed in a discharge tube with an inner diameter of 6.5 mm and a column length of about 70 cm. Flat windows at both ends of the tube has been used to allow the laser beam to pass axially through the positive column. To determine the radial density distribution the tube has been shifted with respect to the laser beam.

3. Results and Discussion

Studies of the pulsed xenon glow discharge at gas pressures between 10 and 40 Torr and peak currents of 100 to 300 mA have been performed. The discharge was powered by a rectangular voltage pulse at a repetition frequency of 6 kHz with duty cycle of 1:1. The rise and decay time of the voltage pulses were about 200 ns. The purity of the xenon gas was 99.99 per cent.

In Fig. 2 the temporal behaviour of the discharge current and of the particle number density of the metastable atoms at a peak current of 130 mA and a pressure of 40 Torr are shown. The sustaining voltage was switched off at the moments $t = 20 \mu s$ and $184 \mu s$ and switched on at about $t = 100 \mu s$. In the early off-phase of the discharge (afterglow) the metastable density increases by about two orders of magnitude, followed by a continuous decrease of the population density. The rise of the density is mainly caused by collision processes between $Xe(2p)$ and ground state atoms and by radiation transitions

from the 2p levels. In the reignition phase of the discharge, a further slight increase is observed. A similar temporal behaviour of the discharge current and the metastable density has been obtained for the entire peak current and pressure range considered.

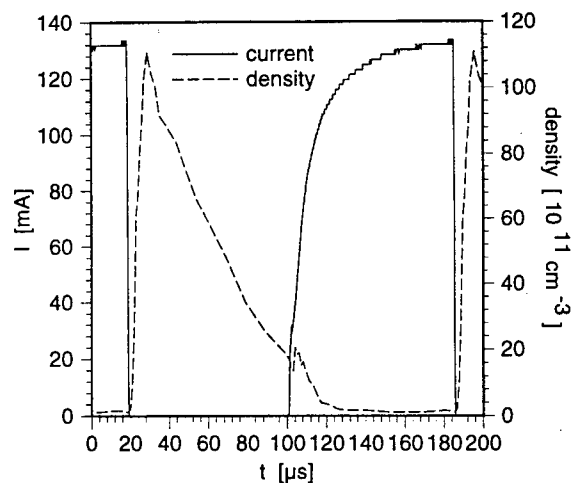


Fig. 2: Temporal behaviour of the discharge current and the Xe(1s₅) density.

In Fig. 3 the radial profile of the absolute metastable density at $t = 40 \mu\text{s}$ is presented. The profile can be approximated by a Gaussian distribution around the centre of the column plasma $N(r) \propto \exp[-(r/r_w)^2]$ with a width r_w of 1.2 mm.

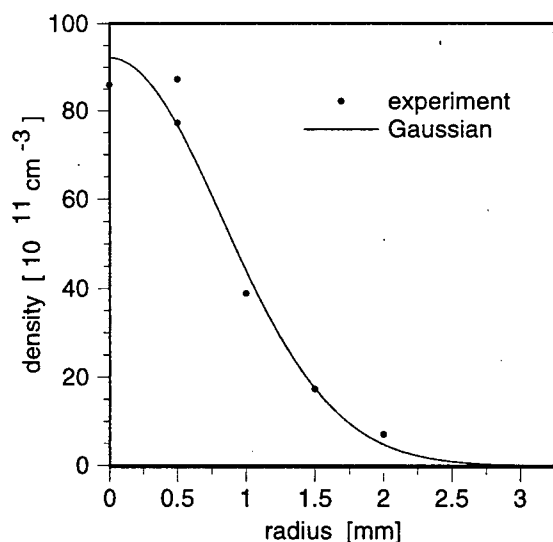


Fig. 3: Radial profile of the Xe(1s₅) density.

The experimental results for the temporal behaviour of the constricted positive column plasma have been compared with the results obtained by model calculations. The self-consistent treatment of the discharge plasma has been obtained by the sim-

ultaneous solution of the time-dependent electron Boltzmann equation, the rate equation system for the relevant heavy particles and the current balance equation for the determination of the axial electric field. A radial averaged treatment of the plasma column has been employed. In accordance with Fig. 3 a Gaussian distribution has been adopted for the radial profile of the electrons, ions and excited atoms and molecules. Fig. 4 shows the measured and calculated temporal behaviour of the axial electric field strength and the density of the metastable atoms. For the electric field a good agreement between experiment and model is obtained. In the afterglow of the discharge the measured and calculated results for the densities agree qualitatively with certain differences in the decay. However, discrepancies between experimental and theoretical results are found in the reignition phase of the discharge. The measured densities are much lower than the calculated ones. In the on-phase of the discharge the course of the latter is very similar to temporal behaviour of the electric field. Although the observed increase of the metastable density during the reignition of the discharge is expected to be accompanied with a rise of the first and second VUV continuum and the near-infrared radiation, no such increase has been measured for the VUV radiation.

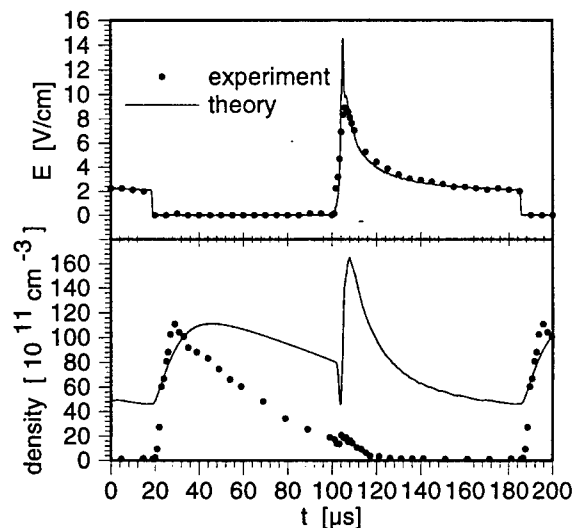


Fig. 4: Measured and calculated temporal behaviour of the electric field and the Xe(1s₅) density.

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Experimental Investigations of Microdischarges in Excimer Barrier Discharge Lamps

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1. Introduction

Dielectric barrier discharges (DBE) in rare gases and rare gas/halogen mixtures are selective incoherent excimer radiation sources with a narrow bandwidth in the vuv and uv spectral range [1,2,3,4,5]. Our investigations deal with the temporal and spatial development of microdischarges in the gas by high speed photography in the ns- and μ s- range. A classification system for microdischarges between large area electrodes is proposed. Interactions between microdischarges are caused both by radiation and by remanent charges on the dielectric and in the gas. Proper interpretation of these results and a corresponding change in operation conditions lead to substantially increased radiation efficiency.

2. Experiment

The measurements are carried out using Xenon (Xe_2^* : $\lambda = 172$ nm), Krypton (Kr_2^* : $\lambda = 146$ nm) and a rare gas/halogen mixture Kr/Cl_2 ($KrCl^*$: $\lambda = 222$ nm) in the pressure range from 100 mbar to 1 bar. We apply sinusoidal voltages with frequencies from 1 kHz to 250 kHz or square wave voltages in the frequency range from 1 - 50 kHz. For the measurements we use both coaxial lamps and flat lamps. A gated, intensified CCD- array camera is used for high speed photography with exposure times from 5 ns up to several microseconds. Both electrical input power and radiation power are measured with high accuracy.

3. Results and discussion

The appearance of the plasma in excimer lamps with large electrodes varies from homogeneous to quasihomogeneous modes to strongly filamented modes with a large number of microdischarges. High speed

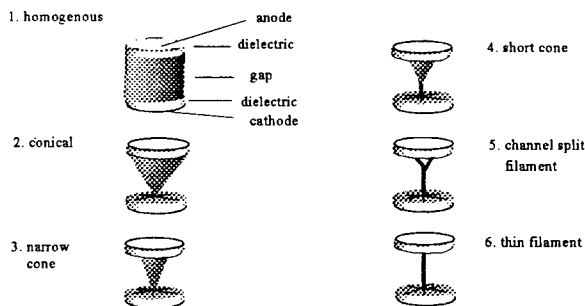


Figure 1: Fundamental types of microdischarges

photography shows a variety of shapes of such microdischarges which can be separated into 6 fundamental types (Fig.1). Rising voltage amplitude or

rising $p \cdot d$ product causes a transition from type 1 to type 6 microdischarges.

The following single frame with 100 ns exposure time shows a homogenous $KrCl_2$ discharge (Fig.2). This type of microdischarge has highest radiation efficiency.

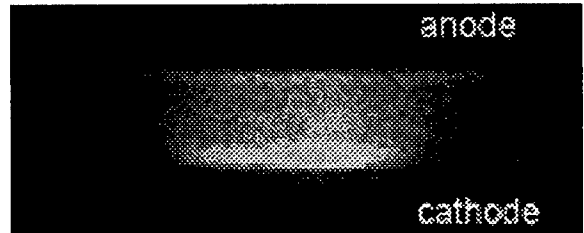


Figure 2: Homogenous discharge: ($Ne/Kr/He-Cl_2 = 700/273/27$, $p = 1000$ mbar, $f = 30$ kHz, gap = 5 mm, diameter = 30 mm, $t_b = 100$ ns)

A typical conical microdischarge is shown in Fig.3. This Xenon microdischarge has a channel diameter of about 3 mm.

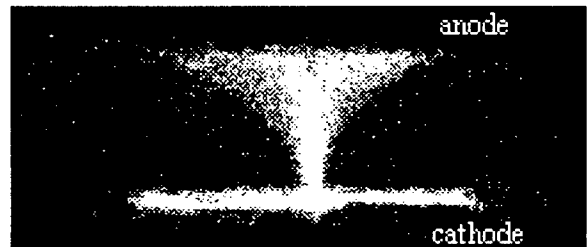


Figure 3: Xenon conical microdischarge ($p = 100$ mbar, $f = 8$ kHz, gap = 5 mm, $t_b = 12$ μ s)

Figure 4 is a single frame with 10 μ s exposure time, showing spatial radiation intensities with a "thin filament" microdischarge according to Fig.1. The

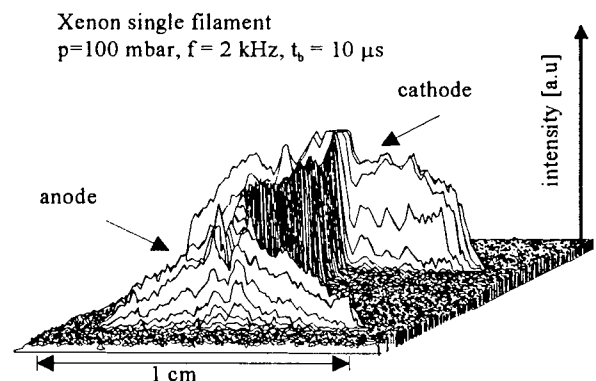


Figure 4: Xenon thin filament microdischarge (gap: 5 mm, $\hat{U} = 3$ kV)

channel diameter between anode and cathode has a width of about 200 μm .

Our measurements show that in the pressure region from 50 mbar to 200 mbar the microdischarges are strongly influenced by preionisation from neighbouring microdischarges. This occurs only if times between microdischarges are less than several tens of ns. Another strong influence is caused by remaining charges on the dielectric barrier. Increasing amplitude or frequency of the applied voltage leads to increasing remaining conductivity also in the gap itself.

By applying different types of driving voltages, it is possible to influence the appearance of the microdischarges, too. There is a homogenizing tendency if square wave voltage drives the lamp. This is only true for lower voltage amplitudes. High voltage amplitudes of the square wave lead to highly contracted and fewer filaments with considerable lower radiation efficiency. Figure 5 shows a comparison of internal radiation efficiencies for a coaxial Xenon lamp for sinusoidal voltage and square wave operating voltage. For the square wave mode the efficiency can be increased at

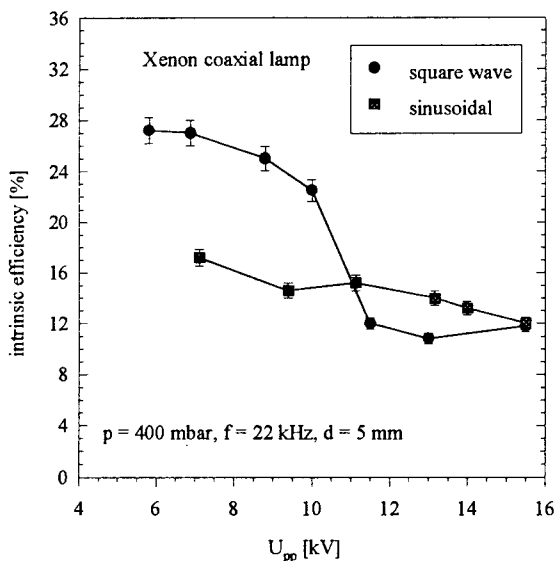


Figure 5: Xenon coaxial lamp: internal radiation efficiency ($\lambda = 172$ nm) for sinusoidal and square wave driving voltages

voltage amplitudes below 10 kV_{pp}. This is due to the existence of "cone shaped" microdischarges in this range. For sinusoidal driving voltages, the discharge consists of either "short cone" (low voltages) or "thin filament" (high voltages) microdischarges.

4. Summary

A classification system for excimer barrier discharge lamps is presented by high speed photographic measurements. Several types of microdischarges can be distinguished. One method of generating conical microdischarges in Xenon is shown by applying other voltage shapes than sinusoidal ones. Homogenous discharge modes and conical microdischarges show highest radiation efficiency.

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Experimental study and modelling of a DC-excited slab CO₂ laser discharge

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1. Introduction

The use of DC-excitation in slab geometries represents an economic route to compact high power CO₂ lasers. In designing these lasers one might take benefit from the predictive capabilities of numerical models of the discharge properties. First, a one-dimensional plasma-chemical model is constructed that computes the charged and neutral particle densities and the self-sustaining reduced electrical field EN (N : density) in a self-consistent way. Next, the set of diffusion equations for the dominant positive and negative ion species is solved along with the heat equation to yield the charged particle density, gas temperature and EN profiles across the discharge gap. These then serve as input for a vibrational kinetics code based on a three temperature model. The results of the plasma-chemical and vibrational kinetics model are compared with experimental data as derived from mass spectrometry and emission spectroscopy respectively.

2. Plasma-chemistry

The first step is to develop a numerical model for the plasma-chemical processes that occur in a slow-flowing CO₂ laser plasma that is uniform in the direction perpendicular to the flow. The model includes reactions [1] such as recombination, attachment, detachment, dissociation and ion-neutral reactions between the different species (neutrals, negative ions, positive ions and electrons). The set of non-linear differential equations, describing the build-up of the particle densities in the discharge and in the flowing afterglow, are solved using the Bader-Deuflhard method for stiff sets of equations [2]. The rate coefficients for electron impact reactions are depending on EN , which in itself is a function of the gas mixture composition. Therefore, for the model to be self-consistent, electrical field and particle densities are to be obtained simultaneously. To this

aim, the continuity equation is added to the set of rate equations. In a flowing plasma the continuity equation takes the form $dj/dt = 0$ where $j = n_e e v_{dr}(EN)$ is the current density and d/dt is a convective derivative in the direction of the flow. Assuming a flat current profile, the inlet electron density n_e can be derived from the total discharge current I and the drift velocity v_{dr} at the inlet value of EN which equals the self-sustaining reduced field of the undissociated gas mixture [3]. The functional dependencies of the drift velocity and the reaction rate coefficients on EN are evaluated from the convolution of the corresponding cross sections with the electron energy distribution function (EEDF), which is obtained by solving the Boltzmann equation with ELENDF [4].

The relative abundancies of the negative and positive ions in the slab discharge are studied experimentally by means of a differentially pumped quadrupole mass spectrometer.

As a next step we calculate the profiles of the dominant charged particle densities and the reduced electrical field across the discharge gap, i.e. perpendicular to the flow. First, the set of diffusion equations is solved for a uniform EN . From the resulting electron density profile the electrical power density $jE(x)$ is computed which serves as the source term in the heat equation. Solving the latter yields the gas temperature profile which is used to calculate a corrected EN profile. This procedure is repeated until convergence is reached.

3. Vibrational kinetics

A three temperature model is used to calculate the energy densities in the vibrational modes. As the input electron density and EN is spatially resolved, the model outputs the vibrational temperature and small signal gain profiles across the discharge gap. To validate the model, the (spatially averaged) nitrogen vibrational temperature is

measured with an emission spectroscopy technique: from the measurement of the relative intensities of the vibrational bands of the nitrogen second positive system ($C^3\pi_u - B^3\pi_g$) the non-equilibrium vibrational temperature T_4^* of the $C^3\pi_u$ -state is derived [5]. The data in fig.1. reveal the decrease of the relative densities of vibrationally excited N_2 molecules with pressure due to the collisional relaxation of the CO_2 (00^0_1) level. Assuming that the $C^3\pi_u$ -levels are populated by direct electron impact, the vibrational temperatures T_4^0 of the N_2 electronic ground state can be calculated using Franck-Condon factors [5]. The latter are found to be about 1000 K lower than the corresponding T_4^* values. It follows that in the homogeneous glow regime 7-16 % of the ground state N_2 molecules is vibrationally excited ($v \geq 1$) and contribute to the population of the upper laser level. Ground state vibrational temperatures in fast-axial-flow lasers are typically higher [6]. However, it should be noted that the use of an uncooled pyrex plate on one side of the slab (for diagnostic purposes) limited the range of accessible power loadings. In fact, the data at 30 Torr suggest a thermal saturation effect.

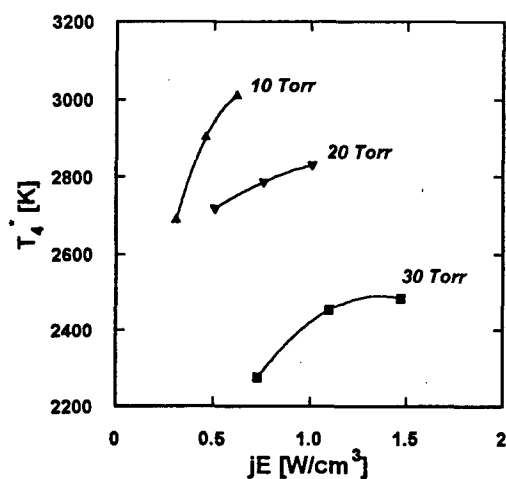


Fig.1. Vibrational temperature of the $C^3\pi_u$ -state of N_2 vs input power density at different gas pressures.

The small signal gain, as derived from the amplification of a probe laser beam, is shown in Fig.2. At a pressure of 20 Torr the recorded values range between 0.45 m^{-1} and 0.65 m^{-1} . The measured gain values are in fair agreement with the results of the three temperature model [7] (full curve). The relatively steep decrease in gain at higher power

loadings should again be attributed to the asymmetrical cooling of the gas. The three temperature model calculations indeed show that substantially higher values of the gain are to be expected if proper cooling is applied (dashed curve).

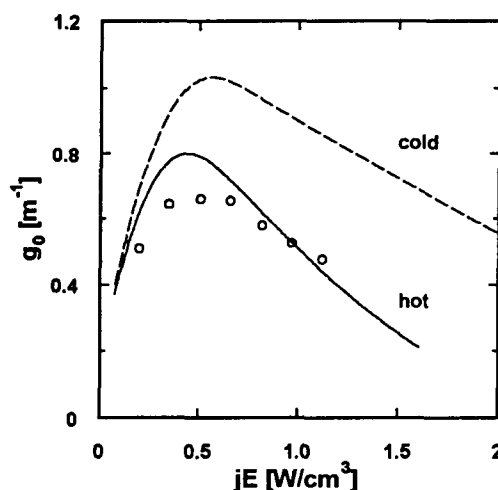


Fig.2. Small signal gain: experimental (O) – three temperature model calculation with pyrex plate (full curve) and with cooling plate (dashed); $p = 20$ Torr.

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VUV emission generation at helium plasma recombination.

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Introduction

At present time there is increasing interest to mercury-free luminescent sources having comparable efficiency as the current mercury-based ones. The choice for the rare gas is explained by a number of factors - available emitting transitions, requirements of efficiency, ecology, safety, reliability and etc. The existing devices use as rule one of the self-sustained discharge schemes that limits the emission generation efficiency at definitive and often not enough high level.

The reduction of reduced field in plasma permits significantly to increase the discharge system efficiency, therefore the transition to non-self-sustained discharge system when gas ionization is provided by an external ionizator could be one of the most effective approaches to VUV emission generation problem. Besides, under these conditions a plasma recombination itself can notably contribute into emitting state excitation.

We have attempted to realize and investigate this approach for xenon-helium mixture by using the open discharge system. Here we present the main results of the experiments on VUV emission generation in pure helium open discharge plasma.

Experiment

The discharge was controlled by three electrodes: copper cathode with a diameter of 20 mm, grounded grid with the cell of 0.04 mm and the transparency of 52%, placed at distance of $d=0.2$ mm from cathode so that a work range of pd parameter (where p is pressure) was on a left side of Paschen curve. The grid anode with the cell of 0.5 mm and the transparency of 80% was placed in 8 mm from the first grid. Either the pulsed or the constant negative voltage U_c up to 1 kV was fed to the cathode, with anode being under the constant positive voltage U_a from 0 to 100 V. Discharge camera was connected with VUV monochromator trough the MgF_2 window. The monochromator was pumped during the experiment and controlled by the programmable step drive.

The open discharge emission in a spectral range of 120-250 nm was detected by solar-blind phtomultiplier with MgF_2 window. The phtomultiplier anode current was fed either to a digital stored oscilloscope or to an electrometric amplifier and then to an analog-digital converter, which were connected with IBM PC by GPIB interface. Currents of all electrodes were measured by the same way.

Results and discussion

A typical emission spectrum of open discharge in pure helium is represented in Fig. 1.

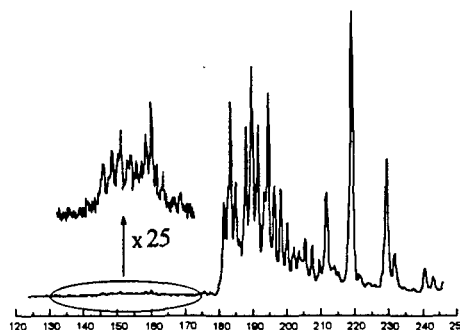


Fig. 1

A typical emission spectrum of open discharge in pure helium, $P_{He}=30$ Torr, $U_c=-800$ V, $U_a=100$ V.

Two spectral features - the first in $\sim 136-168$ nm and the second in $\sim 180-250$ nm - are well-pronounced. The spectroscopic analysis have revealed the main feature in 180-250 nm is due to the transitions between two bounded excited states of He_2 dimer. The pulsed measurements have shown that the observed emission is determined by plasma recombination processes so that one can consider the upper emitting states of He_2 molecule as the autoionized states ultimately bounded up with corresponding vibrational states of He_2^+ molecular ion. The obtained vibrational constants of both the upper and the lower states forming the spectrum as the photon energy have enabled accurately to identify these states. An approximate scheme of the observed transitions is represented in Fig. 2.

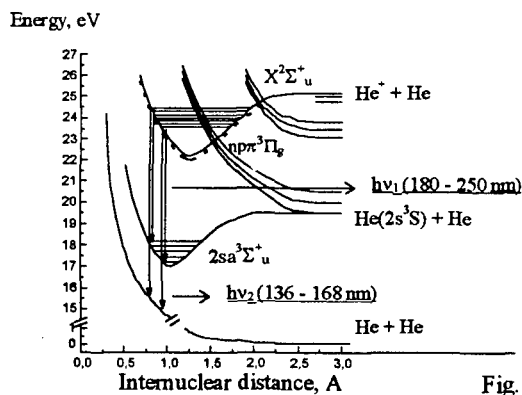
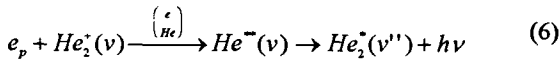
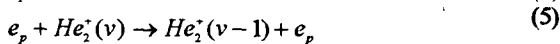
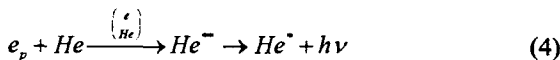
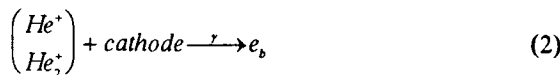


Fig. 2

Scheme of He_2 molecule transitions corresponding to the spectrum shown in Fig. 1

The analysis of spectroscopic data has indicated that VUV recombination emission of $He_2^+(v)$ ion occurs from upper vibrational levels with $v > 10$. In order to provide the observed intensity of recombination spectrum, the population in this vibrational states of $He_2^+(v)$ has to be enough high that can be explained by a relative arrangement of He_2^+ and He_2^+ potential curves. Just the mutual position of He_2^+ and He_2^+ molecular terms is responsible for the branching of He_2^+ recombination stream on the different channels. Like in light ions of H_2^+ and H_3^+ the potential curves arrangement in He_2^+ - He_2^+ system is so that there is some group of He_2^+ molecule high vibrational levels placed far from the intersection points with He_2^+ repulsive states. The probability of fast dissociative recombination for this levels is low enough so that the VT-relaxation and impact-radiative recombination by slow electrons are the main channels of the losses of the level population [1].

Thus the basic processes of VUV emission generation in helium open discharge can be represented by the next kinetic scheme:



($v \sim 4 \div 6, v > 16$)

The (1) and (2) processes describe the electron beam formation in cathode-grid space [2]. Beam electrons rapidly run through this space, accelerating up to the energy equal to a cathode potential. This fast electrons have a wide energetic distribution function in a range of hundreds of electronvolts, i.e. in energy range close to maximum of helium ionization cross-section. It leads to an effective ionization of gas in grid-anode space. Atomic ions as well as formed molecular ions of helium in grid-anode space drift to the grid and then fall in the strong field of grid-cathode gap where they are accelerated to high energies. Accelerated ions effectively strike the cathode and knock γ -electrons which in turn take high energy in grid-cathode electric field, produce the following gas ionization and increase the plasma concentration thereby leading to the process development. Therefore concentration of recombining plasma in grid-anode space can reach a

significant value up to 10^{12} - 10^{13} cm^{-3} , that at lowered pressures about 10-40 Torr when He^+ are the main ions causes the intensive recombination stream to the $He_2^{++}(v)$ formation.

Simplified analysis of (1)-(7) kinetic scheme by using the "steady-state" approach and experimental data for the various pressures, currents, cathode and anode voltages enables to estimate a scaling factor for the branch ratio $\frac{\beta_r^R}{K_r^e}$ in dependence on v - quantum number of $He_2^+(v)$ vibrational state (where β_r^R - is a "general" rate constant of $He_2^+(v)$ recombination and K_r^e is a rate constant of VT relaxation by slow electrons). This dependence is shown in Fig. 3.

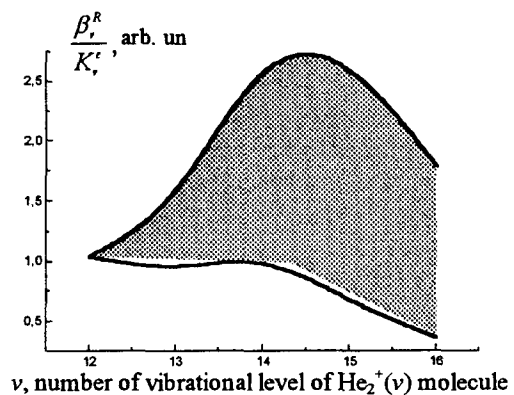


Fig. 3
Scaling dependence (in arb. un.) of $He_2^+(v)$ quenching branch ratio between the channels of recombination and VT relaxation by electrons.

The shaded region between the curves indicates on possible positions of $\frac{\beta_r^R}{K_r^e}$ dependence. The estimate of the branch ratio scaling confirms our considerations.

A growth of $\frac{\beta_r^R}{K_r^e}$ with the vibrational level number is possible only if these vibrational states are placed far from the intersection with He_2^+ terms. In turn the decrease of this ratio at $v > 15$ can be explained by the proximity of similar intersection and a noticeable contribution of dissociative recombination in $He_2^+(v)$ quenching.

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Cross-talk in an AC Matrix Plasma Display Cell: 2D Interactive Simulation

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1. Introduction

Plasma display panels (PDP's) occupy now a central position in the competition for the market of large diagonal (more than 40 in.) flat panel displays for television applications. Japanese manufacturers have announced mass production of such displays in 1996. However some of the characteristics of PDP's still need to be improved (e.g. the efficiency of PDP's is still rather low, on the order of 1 lm/W; also cross-talk problems, i.e. optical or electrical interaction between cells can appear for high resolution). In this abstract we present results from the modeling of AC plasma displays in a matrix electrode configuration. The typical geometry of a simulated PDP domain including one discharge cell and two half cells appears in Fig. 1. In this matrix electrode geometry, the two parallel plates are separated by a typically 100 μm gas gap filled with a UV emitting rare gas mixture (e.g. Xe-Ne) at a pressure on the order of 600 torr. The electrodes on each plate are parallel (with a distance between electrodes on the order of 300 μm) and the two sets of electrodes are perpendicular, forming the lines and columns of a matrix. A discharge can be fired at the intersection of each line and column. The electrodes are covered with a dielectric layer and dielectric barriers are deposited along the electrodes on the back plate, in order to better confine optically and electrically the discharge cells. Phosphors are used to convert the UV light from the discharge cells into visible light. A MgO layer (large secondary emission coefficient by ion impact) is deposited on the dielectric layer above the electrodes. Other geometries, where the discharges occur between coplanar electrodes, the electrodes on the other plate being used for addressing, are also being developed.

In AC PDP's a square wave (typically 50 kHz) voltage is constantly applied between lines and columns. The amplitude of this 'sustaining' voltage is below the breakdown voltage of the mixture. A cell can be turned on by applying, across the electrodes defining this cell and during a short time, a 'firing' voltage above the breakdown voltage. Breakdown occurs and a transient glow discharge forms. This discharge is quenched by the charging of the dielectric surface.

When the sustaining voltage changes sign, another discharge is initiated because the induced voltage due to the charge stored on the dielectric surface adds to the sustaining voltage. The 'ON' state of the cell is therefore a succession of current pulses whose typical duration is on the order of 100 ns. The cell can be turned off by

applying a smaller voltage across the cell, in order to cancel the memory charges.

We present here results from a 2D user-friendly model which can simulate the discharge evolution in one or several adjacent cells.

2. Description of the model

The physical basis of the model is similar to those of the 1D models described in [1] and [2] where charged particle transport equations (continuity and momentum transfer equations) for electrons and ions are coupled with Poisson's equation for the electric field. The system of transport equations is closed with the local field approximation whose validity has been checked by comparisons between 1D fluid and hybrid models. The excited species kinetics is supposed to be decoupled from the discharge model, and this is reasonable for these relatively low current transient discharges. This has been checked by comparisons with the model of [2] where the excited species kinetics were included.

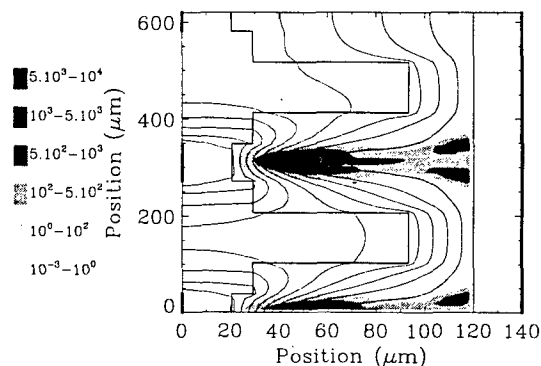


Figure 1: Potential distribution (lines) and power dissipated (W/cm^3) in xenon excitation (gray) at the time of maximum current. The increment between potential contours is 28.4 V. Xe(10%)-Ne(90%) at 560 torr; secondary emission coefficients 0.5 and 0.05 for neon and xenon ions on MgO, respectively.

The present model is identical to the one used in [3] and assumes a Cartesian 2D geometry with symmetry imposed in the transverse direction. The electrode configuration, dielectric geometry, gas mixture etc... can be changed interactively by the user and the results can be visualized in the form of movies as the program is running (one discharge pulse can be simulated in about 30 minutes on a PC pentium).

3. Results

The 2D model is used to study the interaction (cross-talk) between adjacent cells. We simulate the behavior of three adjacent cells when two of them are fired and study the effect of the dielectric barriers and cell dimensions on the electrical interaction between the cells.

The gas mixture is Xe(10%)-Ne(90%) at 560 torr. At $t=0$, the voltage of the two bottom left electrodes is set to zero, the voltage of the right electrode is set to 284 V, and the voltage of the upper left electrode is set to 142 V. Since 284 is above the breakdown voltage and 142 V is below, a discharge is initiated in the two bottom cells and the third cell stays in the OFF state. Figure 1 shows the potential distribution and the dissipated power density in xenon excitation at the time (162 ns after the voltage is applied) of maximum current. The current pulse is displayed in Fig. 2. The spreading of the discharge on the right dielectric surface (anode side) is due to the charging of the dielectric surface, as described in [3]. The simulation of the subsequent sustaining pulses shows no evidence of interaction between adjacent cells in these conditions..

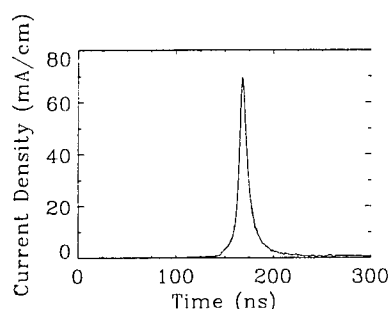


Figure 2: Time variation of the current density collected by the right electrode in the conditions of Fig. 1.

Figure 3 shows the potential and power dissipated in xenon excitation for the same gas mixture and gap length, but without dielectric barriers. We see that the discharge is less confined electrically and its transverse extension is much larger. The presence of the dielectric barrier in Fig. 1 leads to a larger axial field next to the dielectric surface which controls the spreading of the electrons along the dielectric surface. It appears from the simulation of the subsequent sustaining pulses in the case of Fig. 3 that the adjacent cells strongly interact electrically and that it becomes impossible to control separately the adjacent cells.

Figure 4 shows the potential and power dissipation in xenon at the time of maximum current for the 11th sustaining pulse after the writing pulse for a geometry where the gap length is increased to 160 μm , everything else being kept the same as in the geometry of Fig. 1. The height of the dielectric barriers is therefore relatively smaller in this case. One can see clearly the

effect of the electrical interaction between adjacent cells in this figure.

4. Conclusion

A two-dimensional model has been used to quantify the electrical interaction between adjacent cells in a matrix PDP. The height of the dielectric barrier is an important parameter and should be large enough to prevent electric interaction between the cells.

5. Acknowledgments

This work has been supported by Thomson Tubes Electroniques. The calculations have been performed with SIPDP-2D, a Kinema Software product.

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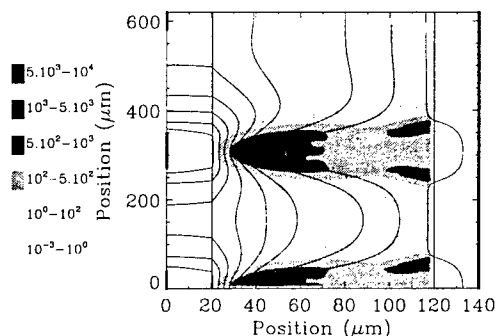


Figure 3: potential and power in xenon excitation at the time of maximum current in a geometry without ribs and phosphors.

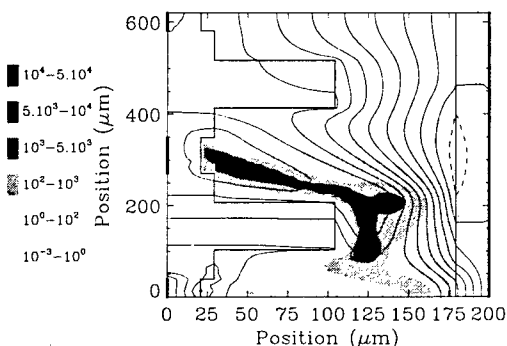


Figure 4: potential contours (lines, increment 31 V) and power dissipated in xenon excitation (gray) at the maximum of current time in a geometry similar to that of Fig. 1, but with a gas gap of 160 μm , during the 11th sustaining pulse. The height of the dielectric barriers is not large enough in these conditions, and the discharges in adjacent cells obviously interact in this example.

Production of capillary discharges for the study of discharge pumped soft X-ray laser

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1. Introduction

Since 1984, when for the first time a high gain has been observed on a soft X-ray transition [1], a run to short wavelengths laser began. Hence, during the last ten years, several laboratories around the world developed what is currently called "soft X-ray laser", exhibiting transitions from 100 nm down to the water-window range. A laser emitting in X wavelength range can be of practical use for many domains such as physics (atomic physics, solid-state physics,...), biology (studies of biological cells, radiography,...), micro-electronic and micro-technology.... Probably many applications have not been yet identified.

Up to date, most of demonstrated X-ray lasers are laser pumped by very powerful laser. For example, the LLNL group obtained unique performances with X-ray laser peak power up to 32 MW and extracted laser energy of 7 mJ at 15.5 nm in Ne-like Y plasma using the largest laser facility by the world [2]. This way of pumping gives excellent results but also shows several inconvenients as very low wall-plug efficiency and repetition rate. Moreover access to these very large devices is rather difficult and then can limits potential applications. Several groups turned towards the development of new pumping methods and promising results have been obtained by reducing the size of pumping lasers with energy as low as 70 mJ [3] but evidently at the expense of the extracted laser energy. A very interesting way came from capillary discharges-created plasmas in vacuum with wall ablation or at low gas pressure. A hot and dense plasma contained within capillary walls is formed by magnetic compression (pinch effect) on capillary axis.

Different kinds of discharges were used as switch triggered discharges, discharges triggered by gas injection or uncontrolled discharges. Hence most of groups used straight capacitors discharges which is definitively the easiest approach to get energy transfer to the amplifying medium. In these cases, discharge voltage is limited by electrical breakdown voltage which imposes constraints on storage capacitance that directly affect the current pulse length, and then the obtention of a skin effect near the tube walls. To get suitable current pulse and good energy coupling, a special care must be taken to adapt the electrical circuit impedance to plasma impedance.

After all, very interesting and encouraging results have been obtained in recombination pumping scheme. For example Shin et al. [4] as well as Steden et al. [5] obtained soft X-ray amplification in the CVI Balmer- α line at 18.2 nm using different types of direct discharges. Impressive results in collisional pumping scheme in Ar-plasma have been obtained by Rocca's group at Colorado State University (USA). They report the first demonstration of saturated operation of a discharge-pumped soft X-ray laser and the generation of laser pulse energies up to 30 μ J at 46.9 nm on the 3p-3s J=0-1 transition in a Ne-like Ar plasma in double pass amplification experiments [6]. Such significant results have thus imposed a completely different approach for discharges structures. The production of the plasma in a low pressure medium (700 mTorr of pure Ar) makes use of a small transfer capacitor charged by a Marx generator under a high voltage (\approx 100-400 kV) then avoiding the increase of the FWHM current pulse.

2. Experimental set-up and results

In a first stage experiment, we studied and developed capillary discharges structures to get ASE (Amplified Spontaneous Emission) quite similarly to what have been recently performed by Shin et al. The experimental set-up is shown in figure 1.

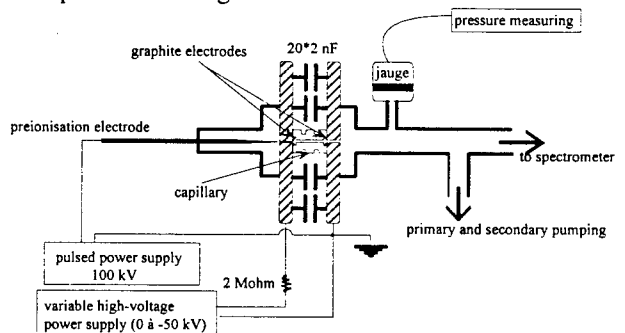


figure 1 : diagram of the experimental set-up.

The capillary is on the axis of a circular flat plates that hold 20x2 nF-knob capacitors mounted in parallel. This geometry provides a low inductance circuit which is favourable to get a high power density. Capacitors are charged by a 50 kV power supply and discharges through a 1 mm-diameter and 19 mm-length capillary. Two different materials containing carbon, polypropylene and polytetrafluorethylene, were used for

capillaries. A preionization electrode connected to a 100 kV pulsed power supply is used to trig the main discharge. Measured current reached 27 kA at 32 kV applied voltage (corresponding to 21 J stored energy) with a pseudo-period of around 230 ns. Strong ablation of walls was effective and led to transient pressure rise that could be measured in the vacuum chamber connected to the X-UV spectrometer. The detection system consists of a Spartuvix-type spectrometer [7] equipped with rapid photodiodes or MCP array detector coupled to a high-resolution ICCD camera. Spectroscopic studies in the visible domain has been performed allowing to follow time evolution of CIII lines. Detailed X-ray spectroscopy of the carbon plasma is under progress. Special care has been put on protection of X-ray optics that can be damaged by particles ejection from capillaries. The system is presently being equipped with a synchronised fast shutter that will prevent debris damage of X-ray mirrors and gratings. To overcome difficulties link with straight capacitor discharge systems, especially pre-breakdown, we are presently studying discharge devices using a new type of pulse forming line (PFL) based on a Blumlein-like PFL. The two main advantages of this type of devices are that, first, they give the possibility to get energetic and very short rise time pulses which are necessary to obtain effective plasma compression and, second, the two electrodes of the capillary are initially at ground potential which prevents pre-breakdown. These systems can be operated at moderate voltage. They are well-adapted for operation in repetitive mode. Objectives to be reach are the following:

- $U=40$ kV
- impedance: $Z = \sqrt{L/C} \leq 1 \Omega$
- $I_{\max}=100$ kA
- $dI/dt \approx 10^{12}$ A/s
- $E_{\text{stored}}=100$ J

Main differences with the Rocca's experiment lie in the value of the used high-voltage and, probably, in the value of the circuit impedance of the system. A special care must be taken to determine the geometry of Blumlein line as it plays a significant role on impedance adaptation. Hence, we conducted studies on different geometries in which we tried to decrease as low as possible the impedance Z -value down to the matching plasma impedance at pinch moment of about 0.3Ω . These first studies revealed that circular plates line geometry might be of great interest as inductance increases only with the radius logarithm whereas capacitance increases with the squared radius of plates then providing a small impedance value and a large stored energy.

We report here experimental and theoretical studies on electrical parameters of this original pulse forming line. Preliminary experiments on different lines have recently been made to better understand the geometry influence on voltage and current evolution, and compare circuit behaviours between circular plate Blumlein and conventional ones. Measured voltage and current time

evolutions has been compared with the ones obtained from the resolution of the set of differential equations derived from the analysis of the equivalent electrical circuit. This was necessary to conduct Z-pinch numerical simulations. As shown on figure 2, there is a rather good agreement between experimental results and model.

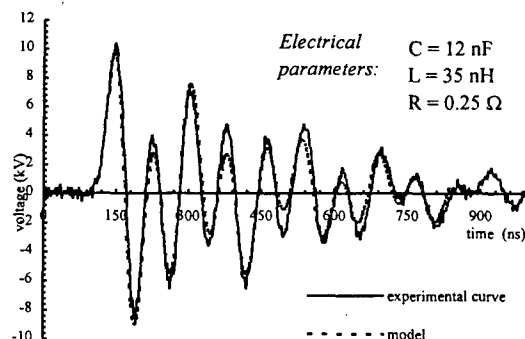


figure 2 : Comparison between experimental and theoretical voltage evolution with time.

Then the calculated current was coupled to Miyamoto's model [8] to study the Z-pinch effect by varying different parameters. Proceeding in this way, we have access to the time-evolution of the plasma radius and then estimate the corresponding temperature, density and ionisation degree. This is important to optimise the energy coupling considering the pinch effect efficiency.

3. Conclusion

In this work, both ablative capillary discharges in vacuum and Z-pinch capillary discharges in low pressure gas have been investigated. Blumlein PFL appear as convenient means for production of capillary discharges dedicated to the study of discharge pumped soft X-ray lasers. They allow a good control of discharge ignition and main discharge parameters. They are particularly well suited to repetitive mode and compact size systems.

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Generation of High-Power Microwaves due to propagation of a relativistic electron beam in plasma

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I. INTRODUCTION

In this paper, we present the last results concerning the interaction of a high-current relativistic electron beam (REB) with a spatially - confined plasma. This interaction is fundamental in the plasma Cerenkov oscillator (P.C.O) or plasma Cerenkov maser, experimental device which consists in transferring the kinetic energy of a relativistic electron beam into electromagnetic radiation. It was shown earlier [1] that single-particle stimulated Cerenkov radiation takes place, microwave power of 100-300 MW was achieved with an efficiency of 10-15 % in power [2]. In our latest work, microwave spectra were measured [3] and calculated [4]. It was shown that the mean frequency and spectrum width could be changed by variation of plasma frequency and transverse structure of electron beam and plasma. All these investigations have been performed for a beam energy up to 650 keV and 3 kA. An other setup has been launched in Ecole Polytechnique permitting the increase of beam energy up to 1 MeV. We shall discuss here the behavior of the oscillator for both regimes of electron beam : 500 keV, 2 kA and 1 MeV, 5 kA.

II. EXPERIMENTAL RESULTS

The setup used for our experimental investigations is displayed in Fig. 1. The hollow relativistic electron beam (1) is generated by the explosive cathode (2). The hollow plasma column (3) is created by a discharge obtained after the propagation of a low-energy electron flux from the heated cathode (4) in xenon. REB and plasma are immersed in a strong longitudinal magnetic field (5). An additional coil (6) permits tuning the plasma radius. Both REB and plasma are lost to the collector (7), that is simultaneously a part of the outlet coaxial horn (8).

The pulse shape of the microwave signal has been measured with a semiconductor crystal detector cooled by liquid nitrogen. The radiated energy by a calorimeter. The beam current oscillogram has a width

of 20 ns and the influence of the plasma density and of the beam - plasma radial gap on the radiation power spectrum is investigated for both beam regimes.

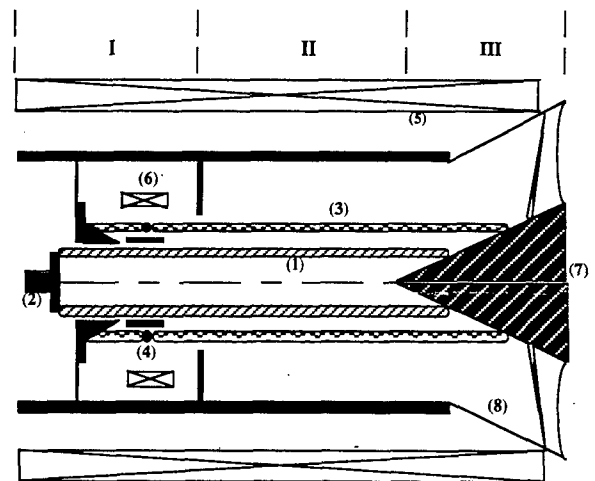


Figure 1. Experimental setup scheme of the Plasma Cerenkov Maser studied in Ecole Polytechnique (France) and General Physics Institute (Russia) : I: Plasma and beam creation zone. II: Interaction zone. III: Emission zone.

The results of the measurements are shown in Fig. 2a for $E = 500$ keV, $I = 2$ kA and in Fig. 2b for $E = 1$ MeV, $I = 5$ kA. These two series of shots have been obtained for a plasma column radius of 8.0 mm. The dependence of the radiated energy and power versus the discharge current is represented. In this range, this current has approximately a logarithmic growing with the plasma density. From the similar behavior of power and energy curves of Fig 2a, it is found that the pulse duration of microwave signal does not change significantly with increasing plasma density. The maximum efficiency in power is obtained for a plasma density slightly above the generation threshold and is about 15 % (150 MW of radiation for 1 GW of beam). Beyond this maximum, the efficiency slowly decreases. Fig. 2b shows the same characteristics. Note however

that the efficiency has diminished to 10 % (500 MW of radiation for 5 GW of beam). We have also studied the influence of the plasma column radius on the radiated power and energy. For a radius of 10.5 mm, we found the same behavior versus the plasma density. The differences between two series of shots corresponding to two different radii are comparable to the accuracy of our measurements.

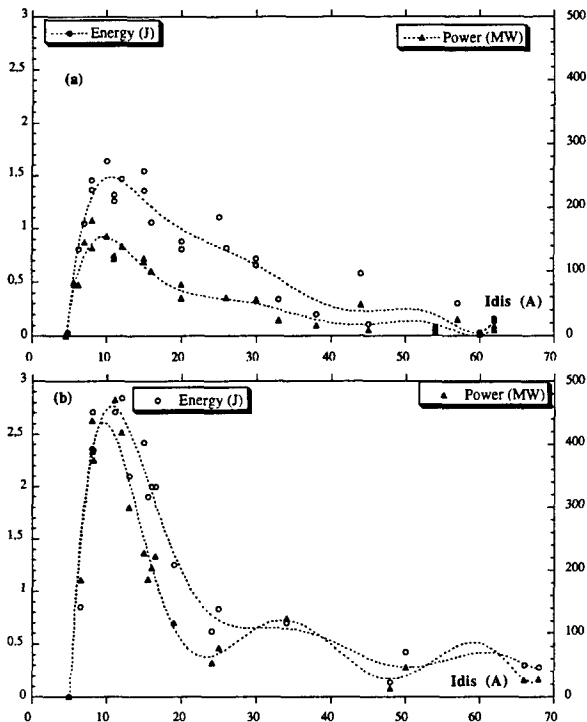


Figure 2. Measured microwave energy and power for $E = 500$ KeV, $I = 2$ kA (a), and $E = 1$ MeV, $I = 5$ kA (b) versus the discharge current.

III. NUMERICAL RESULTS

We have created a numerical model to describe the interaction between the relativistic electron beam and the plasma waves. This code assumes an infinitely thin plasma and beam column in a strong longitudinal magnetic field, a linear behavior of plasma motion and a narrow band spectrum of emission. It takes into account the finite dimensions of the interaction region by reflecting at its longitudinal boundaries a certain part of the microwave signal, and considers the finite beam pulse shape. In this framework, we have studied the dependence of the interaction efficiency versus the plasma Langmuir frequency for the two experimental beam parameters. The result is displayed in Fig. 3. The dependence shows similar behavior to the experimental measurements: a sharp threshold in plasma density and a maximum located near this threshold. For the regime of 500 keV, the maximum efficiency (10 %) in energy corresponds to a power of 180 MW and describes correctly the experiment. When the energy of the beam

is increased from 500 keV up to 1 MeV, the threshold of plasma density shifts to a lower value and the maximum efficiency increases up to 14 %. These two phenomena have not been observed in the experiment.

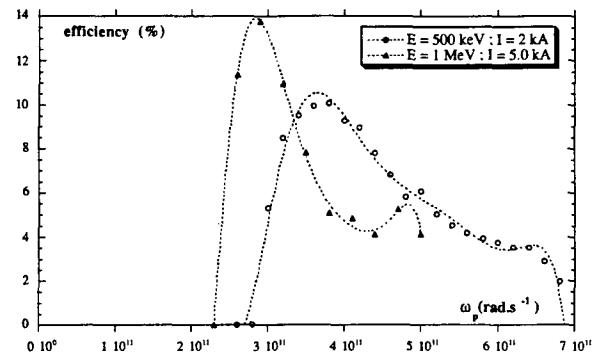


Figure 3. Calculated efficiency of the plasma oscillator for two regimes of relativistic electron beam versus plasma Langmuir frequency.

IV. CONCLUSIONS

Radiation spectrum measurements have been performed using a wide - aperture calorimetric spectrometer in the frequency range 3 - 40 GHz for an electron energy of 500 keV [3]: it was shown that the mean frequency of radiation could be tuned by increasing the plasma density. Numerical simulations confirmed this main behavior. New results concerning the spectrum for the beam energy of 1 MeV will be presented at the conference and compared to the numerical predictions.

The efficiency and the tunability of the plasma Cerenkov oscillator are of interest for a wide range of applications. Also, the reported experiments are a prime necessity to validate the numerical treatments of the beam-plasma interaction.

Acknowledgements. We acknowledge the support of DGA-DRET, contract n° 40-95-007-00.

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Improvement of the metal vapour distribution in CCRF excited metal vapour lasers by cataphoresis

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1. Introduction

Three types of metal ion lasers were realized using a capacitively coupled radio frequency (CCRF) excited discharge as an active medium. Since many years He-Cu⁺, He-Cd⁺ and He-Zn⁺ laser are well known as hollow cathode lasers [1]. Due to the similar plasma properties, inversion on the same metal ion lines can be achieved in the CCRF excited discharge [2].

A homogenous metal vapour distribution along the discharge tube is of main importance for a stable and powerful laser operation. This is incompletely achieved if the metal vapour is only supplied from an external oven and distributed only by diffusion along the tube. With the intention to improve the metal vapour distribution by the effect of cataphoresis a DC current is superimposed on the discharge along the tube. For this purpose the tube is supplied by a DC anode and a DC cathode. The vapour is feeded into the tube from an oven attached to the tube at the anodic side.

Measurements have clearly shown the dependence of the resonator power on different discharge parameters for the three metal ion lasers. To measure the metal vapour distribution the intensity of strong metal atom and ion lines were recorded along the discharge tubes. These spectroscopic measurements demonstrate that the cataphoretic effect improves considerably the metal vapour distribution.

As the investigated lasers have potential UV laser lines, i.e. 193.0 nm for zinc, 248.6 nm for copper and 325.0 for cadmium these investigations are useful to realize CCRF excited UV lasers in the next future.

2. Tube design

The measurements were performed using He-Cd⁺, He-Zn⁺, and He-Cu⁺(CuBr) lasers. The tube construction of the lasers is shown in Fig. 1. The tubes were made of fused silica with an Al₂O₃ tube insert. The inner diameter of the ceramic tube was 4 mm the outer diameter 7 mm. The outer diameter of the fused silica tube was 9 mm. The RF electrodes were made of nickel plated copper with a length of 400 mm and a width of 4 mm. They had a curvature so that they fit on to the outer tube wall. The electrodes were connected via a symmetric matching circuit [3] to a 13.56 MHz RF power supply. The RF power was constantly 400 W during the measurements.

Connecting the anode and the cathode to a DC power supply ($V_{\max} = 5$ kV, $I_{\max} = 350$ mA) a DC dis-

charge could be ignited in addition to the RF discharge. To protect the DC power supply from RF interference an inductance of 5 μ H was placed in the cathode feeding.

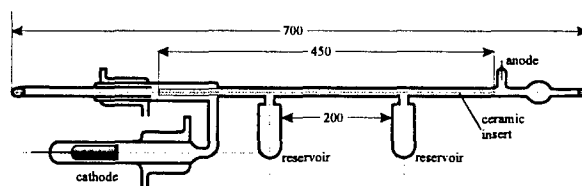


Fig. 1: Tube construction

The metal vapour was produced by two external ovens located equally spaced along the tube. They could be heated separately. So the metal vapour pressure could be controlled independently from the discharge conditions. The part of the tube in front of the cathode was water cooled to avoid that contaminations emitted from the cathode reach the discharge region.

3. Measurements

To investigate the effect of an additional DC discharge the output power of the laser was measured behind one of the high reflecting mirrors.

Fig. 2 shows the laser output power for different He pressures of the 441.6 nm line of the He-Cd⁺ laser. The laser power, which was achieved using the pure RF discharge, was measured with optimized oven temperatures that were nearly the same for both ovens. When the DC discharge was operated additionally only the anode sided oven was heated with an insignificant higher temperature. The DC current was optimized for each pressure to get maximum laser power. It can be seen that the optimum DC current increases nearly linearly with the He pressure. The laser output power could be increased considerably using an additional DC discharge. Furthermore, the pressure optimum is shifted to higher pressures and laser operation is possible at higher pressures, respectively. This behaviour was also observed for the other lines of the He-Cd⁺ laser in the visible and infrared spectral range.

Furthermore, it was observed that the laser output power was more stable when the laser was operated with the additional DC discharge.

The same measurements were performed at the He-Zn⁺ and the He-Cu⁺(CuBr) laser showing a similar behaviour.

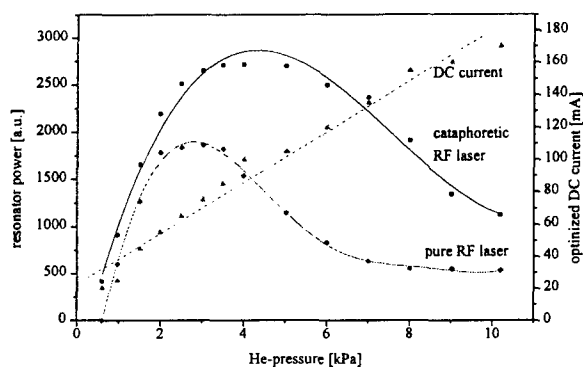


Fig. 2: Laser resonator power of the pure RF and the cataphoretic RF He-Cd⁺ laser line ($\lambda = 441.6$ nm) with the optimized DC current

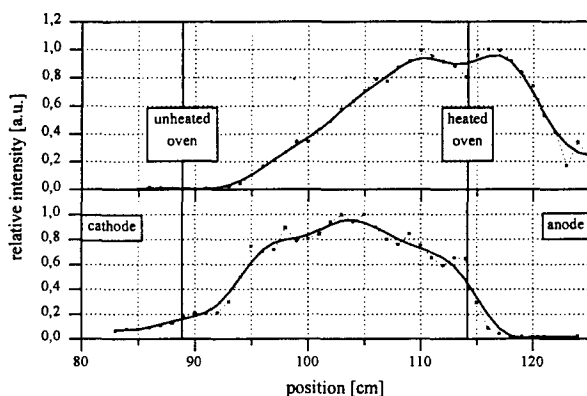


Fig. 3: Intensity distribution of the Cu I 521.8 nm line without and with an additional DC discharge

To determine the distribution of the metal vapour measurements of the side light of the discharge were performed. The side light was recorded along the tube using a 0.275 m spectrograph with a 150 mm^{-1} grating and an optical multichannel analyser. The intensity of a metal vapour atom line was divided by the intensity of an adjacent He atom line at the same position, since He as a gas is distributed homogeneously. So irregularities of the intensity due to deposits on the walls could be eliminated. Fig. 3 shows the results obtained using a He-Cu⁺(CuBr) discharge. The tube had two ovens as the above mentioned He-Cd⁺ laser. The intensity of the 521.8 nm Cu I line was divided by the intensity of the 587.6 nm He I line. The upper part of Fig. 3 shows the Cu vapour distribution if the anodic sided oven is heated without an additional DC discharge. A maximum of the intensity can be observed at the position where the oven is located. The metal vapour density decreases monotonously to the left and to the right side. This distribution is reached by diffusion. The effect of igniting an additional DC discharge can be seen from the lower part of Fig. 3. The metal vapour moves in direction to the cathode. The distribution is more homogeneous. Atomic lines are not excited at the anodic side of the discharge. This demonstrates the effectiveness of the cataphoresis. Since the cathode

sided oven was not heated the metal vapour condenses there and a decay of the line intensity occurs at this position. When also this oven was heated to get a more homogeneous distribution using the additional DC discharge too much metal vapour was supplied to the discharge. So a really uniform distribution could not be reached. Better results are achieved using cataphoresis with a tube supplied only with one oven located at the anodic end of the discharge tube.

4. Conclusions

The metal vapour distribution in CCRF excited metal vapour ion lasers is rather inhomogeneous if the metal vapour is transported only by diffusion. The region of a uniform distribution is limited due to collisions between buffer gas atoms and metal vapour atoms. The higher the buffer gas pressure is, the more collisions occur and the smaller is the region of a uniform distribution. The distribution of the metal vapour is improved considerably if the metal vapour ions are accelerated by an additional DC field perpendicular to the RF field. A higher force is needed to transport the metal vapour ions through the discharge volume at higher pressures. So the positive effect of the additional DC discharge becomes more important at higher buffer gas pressure. Since the metal vapour ions are produced by the RF discharge the necessary DC current to move the ions, is rather low in comparison to positive column lasers.

It was shown that the laser power of CCRF excited metal vapour ion lasers can be increased if the metal vapour is distributed more homogeneously by an additional DC discharge.

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The mean electron energy in RF and HC discharges

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ABSTRACT

The similar laser capabilities of the radio-frequency (RF) and hollow-cathode (HC) discharges are believed to be a result of their similar electric properties. However, there are not many experimental evidences indicating that the plasmas of both discharges resemble each other.

This investigation was aimed at comparing the mean electron energy in the RF and HC discharges run in the same hollow electrode.

1. Introduction

The HC discharge-excited ion gas lasers are attractive because of their capability of generating in the UV spectral range [1]. However some technological difficulties made the HC discharge-excited lasers unpractical. On the other hand, there are some evidences that the capacitively coupled RF discharge is as effective in exciting the ion gas lasers as the HC discharge [2]. It seems that the similarity in laser characteristics of the RF and HC discharges is a result of their similar electrical properties [3]. However, there are few experimental evidences which show that the plasmas of both discharges are similar.

In this paper the results of measuring the mean electron energy in the RF and HC discharges typical of the ion gas lasers are presented.

2. Experimental set-up

The RF and HC discharges were run in He-Cu-sputtered and He-CuBr-based laser systems. The He-CuBr-based laser system is an alternative to the He-Cu-sputtered system in producing Cu^+ ions capable of lasing. The discharge tube for the He-Cu-system is presented in Fig. 1.

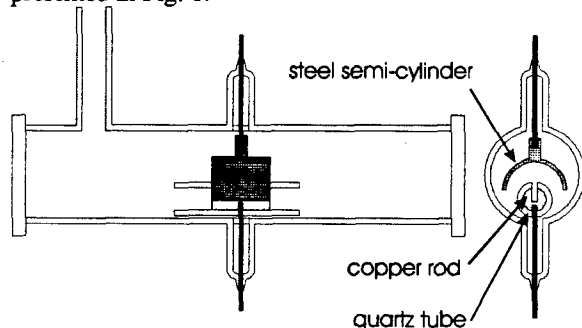


Fig.1 The scheme of the He-Cu-sputtered discharge tube.

In the He-Cu-sputtered system the sputtered part of the copper rod electrode was a slit 3×2 mm made along the rod. The counter-electrode was a stainless-steel semi-cylinder. The copper rod was enveloped in a quartz tube having a slit along the copper slit.

The following power supplies were used to provide either the RF or HC discharge to the He-Cu-sputtered tube:

- for the RF discharge a 13.56 MHz pulsed or cw generator was used. The RF power was supplied to the discharge tube via a symmetric matching circuit [4],
- the HC discharge was supplied with 50 Hz half-wave rectified pulses. The stainless-steel semi-cylinder served as an anode. The slit in the copper rod electrode worked as a hollow-cathode.

The He-CuBr-based discharge tube is presented in Fig.2. The discharge tube was supplied from the RF generator (13.56 MHz) and a DC power supply. Both discharges, RF and DC, were simultaneously run inside the quartz-ceramic tube (40 cm long and 4 mm in diameter). CuBr vapour were delivered inside the tube from a heated CuBr reservoir. After dissociation of the CuBr molecules, Cu atoms were present in the discharge. Due to the DC discharge, cataphoresis effect was produced in the tube to provide a uniform Cu^+ ions distribution in the tube. The Cu atoms were ionized and excited by charge transfer reactions with He ions.

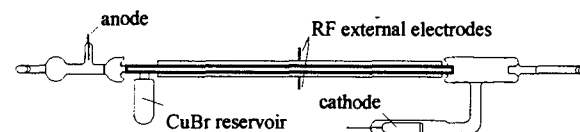


Fig.2 The scheme of the He-CuBr discharge tube.

3. Experimental method

A spectroscopic method based on a condition that the plasma is in local thermodynamic equilibrium (LTE) was used to determine the mean electron energy (E_T). In this model the number of excited atoms in plasma is described by the Boltzmann distribution which depends on the mean electron energy. The mean electron energy can be determined by measuring the relative intensities (which are proportional to the appropriate number of excited atoms) of several lines emitted by the plasma [5].

In order to increase the accuracy of determined E_T and verify the LTE assumption it is necessary to

rearrange the Boltzmann distribution formula into the following equation:

$$\ln \left\{ \frac{\varepsilon_1 f_{m_n}(2) g_n(2) \left(\frac{\lambda(1)}{\lambda(2)} \right)^3}{\varepsilon_2 f_{m_n}(1) g_n(1)} \right\} = \quad (1)$$

$$= -\frac{1}{E_T} (E_m(1) - E_m(2))$$

where: 1 and 2 denotes the measured lines, f_{m_n} is the oscillator strength for the transition $m \rightarrow n$, g_m and g_n are the statistical weights of the two levels, ε_1 and ε_2 are the intensities of the measured lines, $\lambda(1)$ and $\lambda(2)$ are the lines wavelengths, E_m is the energy of the upper level of the transition.

For the case of thermodynamic equilibrium the Boltzmann plot is a linear function of the energy difference $[E_m(1) - E_m(2)]$. The slope of the Boltzmann plot determines the mean electron energy.

For determining E_T the relative intensities of the following lines were used:

He I- 492.2 nm, 501.6 nm, 667.8 nm, 728.1 nm in the case of the He-CuBr laser system,

He I- 492.2 nm, 438.8 nm, 396.5 nm, 388.8 nm and **Cu I-** 578.2 nm, 521.8 nm, 515.3 nm, 510.6 nm in the case of He-Cu sputtered system. The oscillator strengths of He and Cu lines were taken from [6] and [7].

4. Results and Conclusion

The obtained linear energy dependence of the Boltzmann plot suggests that the distribution of the He and Cu atoms over the energetic states has equilibrium character in the investigated discharges.

In every examined type of discharge, E_T almost did not change with changing electric power (see Fig.3).

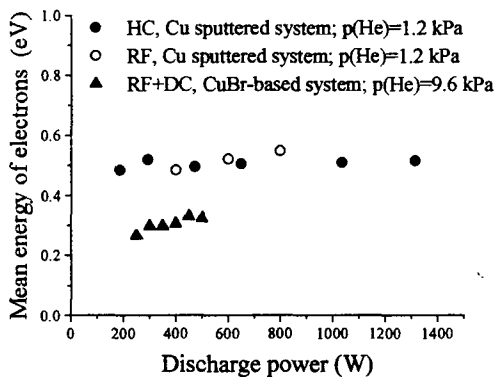


Fig.3 Mean electron energy as a function of delivered power.

On the other hand, the intensity of He and Cu lines increases with increasing input RF power in both laser systems. This means that the increase of atom excitation

with increasing electric power is caused by an increase of the number of electrons capable of exciting the atoms (since the energies of electrons cannot increase when increasing electric power because the operating voltage remains constant).

The mean electron energy in the He-CuBr plasma generated by a combined RF and DC discharge was lower than that in the Cu-sputtered system mainly due to higher He pressure (9.6 kPa).

In conclusion, the obtained results show that the mean electron energies in the RF and HC discharges are similar. In both discharges the bulk of the electrons consists of low-energy electrons characterised by a mean energy of about 0.5 eV. The similar mean electron energies in the RF and HC discharges found in this experiment is another evidence for similarity of both discharges.

Acknowledgment

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Optical, radio and X-ray radiation of Red Sprites produced by runaway air breakdown

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1. Introduction

We use the runaway air breakdown model of upward discharges to calculate optical, radio, and X-ray radiation generated by red sprites. Red sprites are high altitude (up to 90 km) lightning discharges. Aircraft based observations [1] show that sprites are predominantly red in color at altitudes above ~ 55 km with faint blue tendrils, which extend downward to an altitude of 40 km; the duration of a single sprite is less than 17 ms, their maximum brightness is about 600 kR, and estimated total optical energy is about 1-5 kJ per event. The ground based observations show similar results, and provide some additional information on spatial and temporal structure of sprites [2], and on sprite locations [3]. One difference between aircraft and ground-based observations is that blue tendrils are rarely observed from the ground. Sprites usually occur above the anvils of large mesoscale convective systems and correlate with strong positive cloud to ground discharge [4]. Upward discharges are the most probable source of X-ray emission observed above large thunderstorm complexes by the Compton Gamma-ray Observatory [5]. To escape the atmosphere these γ -rays must originate above 25 km altitude. Red sprites are usually observed at altitudes higher than 50 km, and are therefore a likely source of this x-ray emission.

2. Theoretical results

We compute optical, radio and gamma-ray emissions caused by electrical discharges propagating upward in upper atmosphere. The results of the kinetic theory for runaway air breakdown [6] are used in our numerical calculations. We use the air fluorescence efficiencies measured by Davidson and O'Neil [7], and Mitchell [8] to calculate optical emissions. The spatial and temporal distribution of the number density and velocity of charged particles, from computer simulations, allow us to reproduce the corresponding distribution of

optical emissions in space and time. We use extinction coefficients measured by Guttman [9] to calculate the atmospheric attenuation of optical emissions. The maximum intensity of optical emission calculated over 17 ms (corresponding to one camera frame) is 647 kR. Red emission of 1P N_2 predominates at altitudes higher than 55 km. At altitudes lower than 55 km blue emission of 2P N_2 and 1N N_2^+ predominates. We also calculate the radio emissions caused by the upward propagating discharge by using the distribution of electrical current density and charged particle number density in space and time, taken from the numerical simulations of runaway air breakdown.

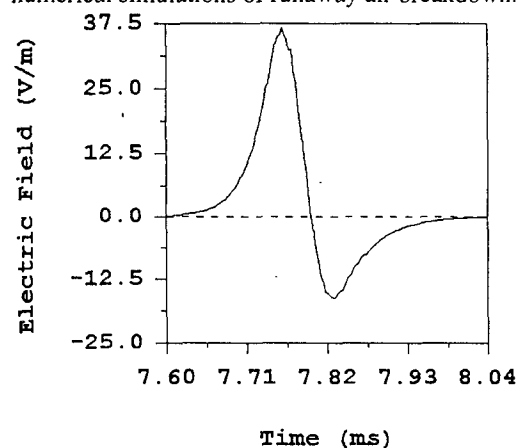


Fig. 1

The electric field of electromagnetic radiation as a function of time for an observer at altitude 80 km and 50 km from the center of the discharge is shown in Fig. 1. The maximum electric field amplitude is 37 V/m. Our results show that the radio emission of upward discharges is comparable with the radio emission of regular lightning. Therefore it is reasonable to conclude that ionospheric phenomena usually associated with radio emission of regular lightning such as ionospheric heating and glowing, lower-hybrid wave generation, explosive spread F and others can be caused by the radio emissions of upward discharges as well. Given the distribution of velocity and number density of relativistic

electrons in space and time we compute the spatial and temporal distribution of gamma-ray flux caused by the upward propagating discharge. In our calculations we use the emissivities calculated by Roussel-Dupré et al., [6] based on the Bethe-Heitler doubly differential cross section for bremsstrahlung emission by a relativistic electron. We take into account gamma-ray photons with energy $E > 30$ keV.

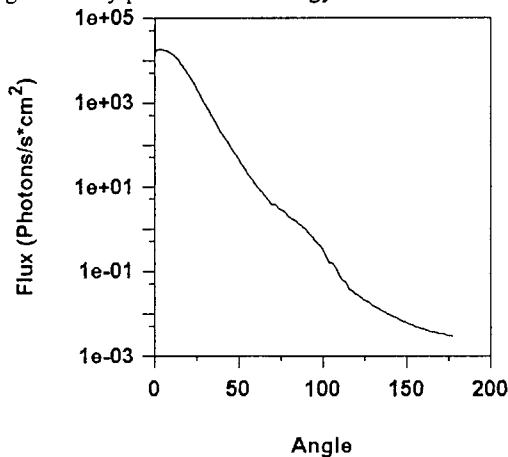


Fig. 2

The gamma-ray flux angular distribution at 1000 km from the discharge center is shown in Fig. 2.

3. Discussion and conclusion

We have compared our theoretical results for optical emissions with observations [1,2,3]. The computed intensity is in excellent agreement with the results of observations [1] measured from aircraft. The peak value measured by Sentman et al. [1], is about 600 kR, which is close to our computed peak value: 647 kR. Our calculations show the presence of visible blue emission at the bottom of the red sprite (blue tendril), which extends downward as low as 40 km. In this case, the blue tendril is visible only from high-altitude platforms ($h \sim 11$ km), and becomes invisible from low-altitude because of Rayleigh scattering and scattering from aerosols. This result is in agreement with ground-based observations of red sprites which show no blue tendril for distant sprites.

The computed values of the gamma-ray flux are in agreement with observational results reported by Fishman et al., [5]. As one can see in Fig. 2, the gamma-ray flux depends significantly on the angle of observation. For an observation angle of 90° the computed flux value is about 0.8

photons/s*cm², for an angle near 0° the flux exceeds 10^4 photons/s*cm². The measured gamma ray flux [5] is about 100 photons/s*cm². We have calculated the gamma-ray flux without taking into account scattering by air. The scattering will lead to increasing the duration of the pulse and simultaneously decreasing the peak flux value. Our simulation shows that an upward discharge has a tendency to produce several short (with duration about 0.1-0.5 ms) gamma-ray pulses with time separation about 0.1-1 ms. These pulses could appear to an observer as one gamma-ray burst with duration 1-3 ms as a result of gamma-ray scattering. Indeed, such fine structure of the gamma-ray burst was observed by [5], and gamma-ray pulses with duration between 1-3 ms usually had multiple peaks.

In conclusion we note that the runaway air breakdown theory explains γ -ray emissions above thunderstorms and the blue tendrils of sprites; two phenomena that can not be explained by any other model of upward discharges.

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Fullerene as the new emitting additive for a low pressure gas discharge light source

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The search of new additives (atomic or molecular), which would be able to replace mercury in luminescent light sources, is continuously carried out by all leading lighting companies all over the world.

This paper deals with the possibility of using a recently discovered substance - a molecular cluster C_{60} which is referred to as fullerene - as an emitting additive of a gas discharge light source.

Several factors, concerning physical and chemical properties of fullerene molecules [1,2], lead to the hypothesis that fullerene can be a suitable additive for a low pressure gas discharge light source.

They are as follows:

- 1) a low ionization potential 7.6 eV;
- 2) theoretically predicted optical transitions between excited levels in a range 200-260 nm (see Fig.1 which presents the levels' structure of C_{60});
- 3) molecules C_{60} do not dissociate during the collisions with fast electrons (up to energy 80-100 eV) or absorb UV photons (with energy up to 30 eV);
- 4) fullerene is stable to heating up to 900-950°C;
- 5) the pressure 10^{-2} - 10^{-1} Torr of fullerene vapour is reached at 600-700°C;
- 6) fullerene molecules have practically no ecological effects;
- 7) it is not aggressive to other materials.

The points 1-3 make it possible to draw a conclusion that under some discharge conditions fullerene molecules, being added to a buffer gas (as mercury, being added to argon in luminescent lamps), can form emission properties, ionization balance in the plasma of a discharge and absorb the major part of applied electric power. Similar picture takes place in mercury luminescent lamps and ensures their high efficacy.

The possibility of using fullerene molecules as the emitting additive in a gas discharge light source was verified on electric discharges in noble gases He, Ne, Ar and Xe. The discharge chambers were made from transparent quartz glass allowing measurement in a spectral range 200-800 nm with the wall heating up to 700°C. Two types of discharge were studied: d.c. discharge and HF inductive discharge at 60 MHz. The noble gas pressure varied within 1-30 Torr and the discharge current density was about 10^{-2} A/cm²; the HF discharge power was high enough for the optical emission to be observed by with the naked eye. Fullerenes were introduced into the discharge either as C_{60} powder or fullerene-containing soot.

The plasma emission spectrum was measured in the range 200-800 nm at various temperatures of the discharge chamber, various gas pressures and discharge current.

The measurements have shown that the heating in the presence of fullerene-containing material leads to

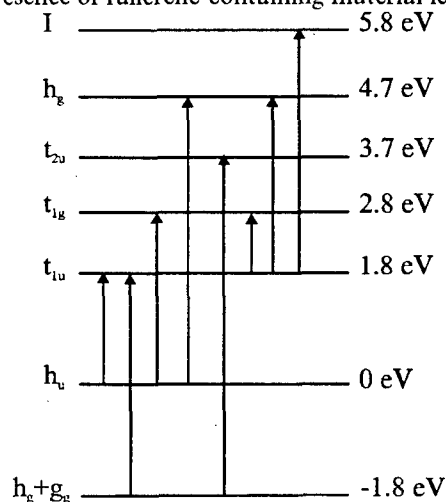


Fig. 1 Diagram of the electronic terms of the C_{60} molecule.

sweeping in the emission spectra for both d.c. discharge and HF discharge. At near-room temperature only noble gas atom lines are present.

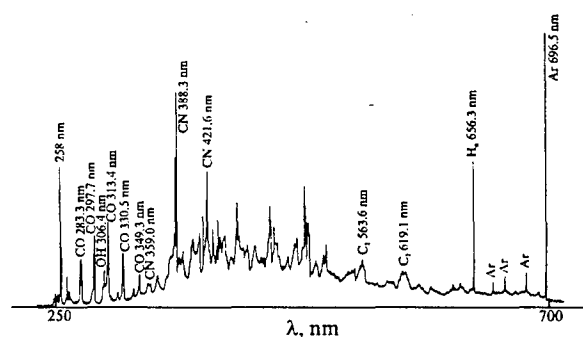


Fig. 2 Emission spectrum of an rf discharge in argon

Increasing temperature and appearance of fullerene vapour "inhibits" these and produces new lines (bands) in the blue-green and UV spectral regions (Fig.2). The lines observed can be identified as C_2 , CN, CO and H lines. These dashes are presented in a fullerene sample and can hardly be eliminated by previous heating up to 150°C. The higher temperature is not used, because it is possible the pre-oxidation of C_{60} [3] and following destruction of the pre-oxyded fullerene. The band in the range 260 nm (see Fig.3) is due to the fullerene vapours in the plasma [4].

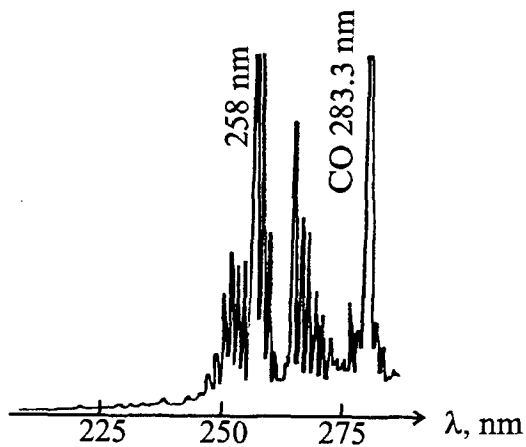


Fig.3 Emission spectrum (near 260 nm) of an rf discharge in argon in the presence of C₆₀ vapor in the gas phase.

The radiation at 260 nm is near the mercury resonance line 254 nm that makes it suitable to use this band instead of mercury line for the excitation of phosphors provided that the intensity at 260 nm is sufficiently high. The latter requires further investigation.

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The effective low pressure gas discharge source of optical radiation based on hydroxyl OH

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Up-to-date low pressure gas discharge light sources are filled with mixtures of a buffer gas and an emitting additive having got, in comparison with buffer gas atoms, low excitation and ionization potentials. The most well-known examples of such light sources comprise mercury luminescent lamps and low pressure sodium lamps. As the capacity of emitting additives alkali metals (Na, K, Rb) and alkali-earth metals (Hg, Cd, Zn) are often used. However these light sources, being remarkable for their very high efficacy, have got some disadvantages the main of which is, in our opinion, their ecological effects.

The paper is devoted to the study of an opportunity of creating a new effective light source of optical radiation based on a practically harmless molecular additive - hydroxyl OH. Molecules OH have ionization potential 12.1 eV which is comparatively lower than that of the light noble gases (He, Ne, Ar), their resonance radiation gives the emission band 306.4 nm, and their preparation from water molecules in a gas discharge medium is not difficult.

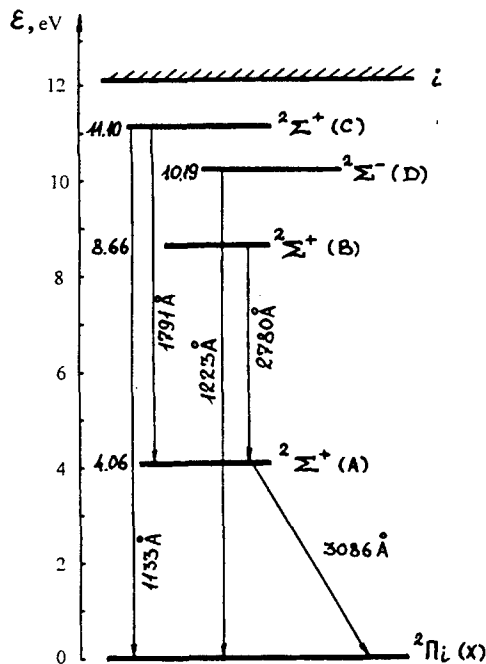


Fig.1 A simplified scheme of the molecule OH energy levels (only electron states are shown, vibrational and rotational structure are omitted).

Discharges in noble gases He, Ne, Ar, Xe were investigated when a molecular additive OH was present in a discharge tube. The pressure of the noble

gases varied in the range 3-30 Torr, the concentration of molecules OH was 10^{13} - 10^{16} cm⁻³ (it was derived from the quantity of water molecules filled in a discharge tube supposing that an electric discharge causes the dissociation of all water molecules H₂O giving H and OH). Quartz discharge tubes 1 cm in diameter were used. Discharge current was 100-500 mA. Plasma emission spectrum in the range 200-800 nm and applied electric power were studied when discharge compositions and conditions were changed. Comparative experiments were also carried out to study the excitation of different phosphors by a mercury luminescent lamp and (OH + noble gas)-discharge plasma to estimate the light efficacy of the latter.

Fig.1 shows a simplified scheme of the molecule OH energy levels (only electron states are shown, vibrational and rotational structure are omitted).

The lower resonance state $^2\Sigma^+(A)$ with excitation energy 4.06 eV gives the emission band 306.4 nm. This radiation can be used *per se*, because it coincides approximately with the maximum of the UV absorption band inherent in biological organisms, and this UV radiation can be also converted into visible range with the help of phosphors.

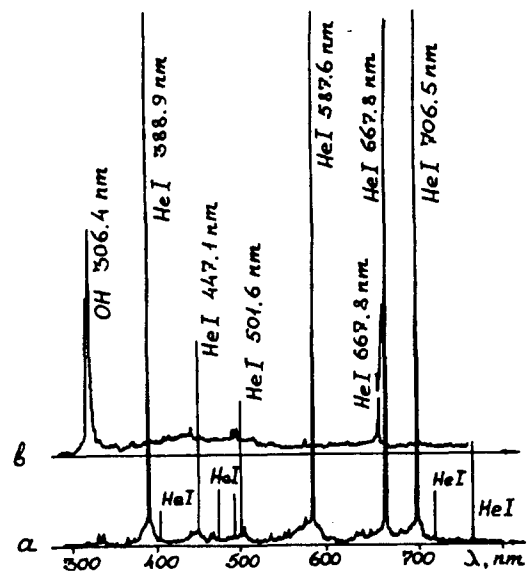


Fig.2 Optical emission spectra of the He-discharge plasma (a) and (He + OH)-discharge plasma (b).

The adding of the molecules OH into a noble gas discharge, as experiment shows, changes plasma

emission and electrical properties dramatically. Fig.2 presents optical emission spectra of the He-discharge plasma (a) and (He + OH)-discharge plasma (b). As one can see from the figure, the presence of the OH-additive in the discharge in question leads to the practically full suppression of the noble gas radiation in the spectral range under study. Instead of them there appeared an intensive emission band OH 306.4 nm. The high intensity of this radiation makes it possible to hope that the major part of the applied electric energy expends on the excitation of the OH-resonance radiation.

Similar results were obtained for the other mixtures of OH and the noble gases in question.

It will be noted that the radiation of atomic hydrogen is not appreciable (choosing discharge conditions the intensity of the hydrogen spectral line $H\alpha$ can be decreased to 10^{-2} of the 306.4 nm intensity) and the radiation of atomic or molecular oxygen which could arise from the dissociation of H_2O or OH is not registered at all.

The estimation of the plasma light efficacy of the discharge is under study, carried out with the help of phosphors excitation, shows good chances for the creation of a new effective source of optical radiation.

Spatially One-Dimensional Modelling of a Stabilized Discharge Pumped XeCl* Laser

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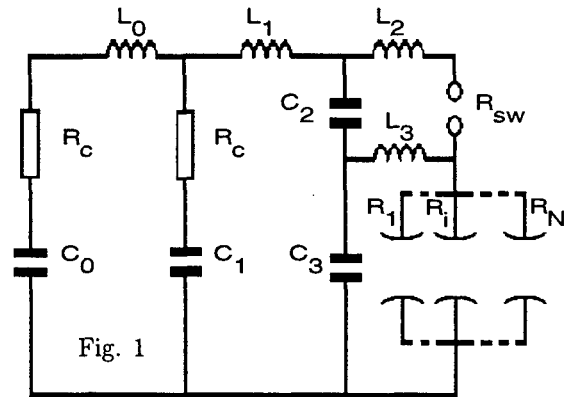
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1. Introduction

To initiate and maintain a homogeneous laser discharge, recently a new arrangement for providing a stable, homogeneous discharge for the pumping of wide-aperture excimer lasers has been proposed in [1]. The suppression of the filamentation of the discharge plasma has been achieved by a special pumping technique which is based on the additional use of a low-current preliminary discharge ahead of the high-current discharge. In the present paper the impact of an inhomogeneous preionization on this excimer laser discharge is analysed. The studies have been performed with a self-consistent spatially one-dimensional model for a XeCl* laser discharge.

2. Description of the Model

In the frame of the model a parallel resistor description [2] of the discharge plasma has been adapted. The total discharge region is divided into a number of spatially homogeneous discharges which are parallel to the discharge current and to the optical axis of the resonator cavity. Each discharge region i is characterized by its cross section area A_i and the initial electron density $n_{ei}(t=0)$ according to the spatial distribution of the preionization. The laser discharge has been treated by self-consistently solving the equation system for the electrical circuit as well as, for each spatially homogeneous discharge region, the time-dependent electron Boltzmann equation including electron-electron interaction for the determination of the electron kinetic quantities and the rate equation system for the various heavy particles and photons occurring in the plasma. The present spatially one-dimensional model is an extension of the spatially homogeneous model described in [3]. Fig. 1 shows the equivalent electrical circuit used in the model calculations, where $C_0 = C_1 = 200$ nF, $C_2 = 1.8$ nF, $C_3 = 0.85$ nF, $L_0 = 2.2$ μ H, $L_1 = L_2 = 40$ nH, $L_3 = 0.5$ nH, and $R_c = 0.01$ Ω . The resistance R_{sw} of a spark gap triggers the transition from the low-current to the high-current discharge phase. The resistance R_i of the discharge region i is determined by the solution of the electron Boltzmann equation for that region. The system of rate equations describes the temporal evolution of 22 heavy particle components and the laser photons and takes into account about 150 collision processes.



3. Results and Discussion

Results of model calculations for Ne/Xe/HCl mixtures with a standard composition of 1000/8/0.8 at a total pressure of 3 bar and a gas temperature of 293 K are presented. The parallel plate electrodes are separated by 8 cm, the discharge length is 60 cm and the width of the total discharge is 5 cm. The optical plane-plane resonator consists of a totally reflecting mirror and an output mirror with a reflectivity of 30 per cent and the cavity length has been chosen to be 80 cm. At the standard initial voltage of 39 kV a laser output energy of 1.4 J with an efficiency of about 1 per cent and a pulse duration of 400 ns was obtained when assuming a homogeneous discharge operation.

To study an inhomogeneous preionization, the total discharge has been divided into two regions, where the preionization electron density $n_{e2}(t=0)$ in region 2 has been chosen to be higher than that in region 1. Thus, the discharge region 2 is assumed to represent the total number of filaments covering the area A_2 . In Fig. 2 the temporal behaviour of the discharge voltage U_d (full line) and of the current density j_i in the discharge regions $i=1$ (short-dashed line) and $i=2$ (long-dashed line) are shown for the case with $n_{e2}(t=0) = 1.05 \cdot n_{e1}(t=0)$ at $n_{e1}(t=0) = 5 \cdot 10^8$ cm^{-3} and $A_1 = 4 \cdot A_2$. After the charge of C_0 is transferred to C_1 and the capacitive divider C_2/C_3 in a prephase of about 1.2 μ s, the low-current phase starts with the preionization of the discharge. In this phase the current density in both regions remains less than about 10 A/cm². Typically after a low-current phase of about 400 ns the high-current phase is triggered. In contrast

with experiments [1] the results for the current densities obtained by the model calculations predict the development of an inhomogeneous high-current discharge. For times later than about 650 ns the voltage is insufficient to sustain the discharge in region 1 and the discharge contracts to region 2.

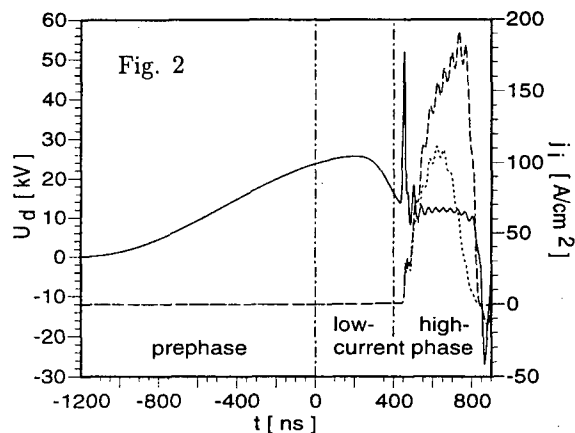
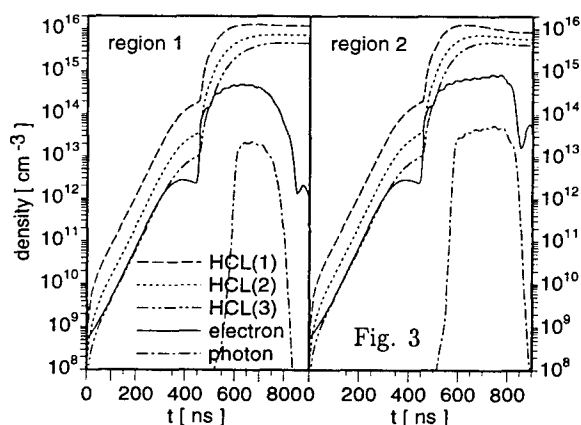
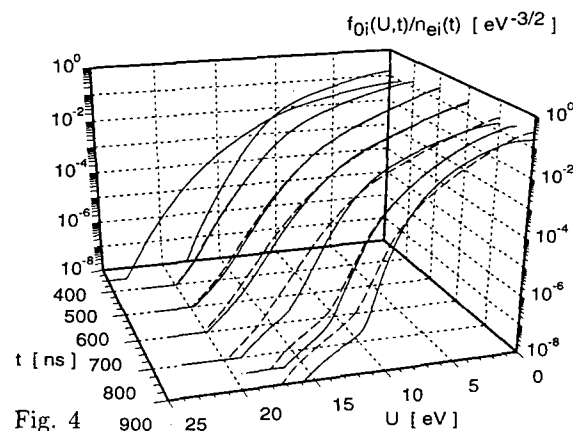


Fig. 3 presents the temporal evolution of the particle number densities of $\text{HCl}(v)$ with $v = 1, 2, 3$, of the electrons and the photons in both discharge regions. During the low-current phase the densities of $\text{HCl}(v)$ and the electrons increase nearly exponentially in both regions. The initially slight difference of 5 per cent between the electron densities increases continuously during the high-current phase up to more than one order of magnitude at the end of the discharge. For $t > 600$ ns the enhanced electron density in region 2 causes a decrease of the $\text{HCl}(v)$ densities in that region, while the densities of $\text{HCl}(v)$ in region 1 remain nearly time-independent. As a consequence of the behaviour of the electron density, the photon density in region 2 reaches larger values and the photon pulse takes longer than in region 1.



In Fig. 4 the isotropic part $f_{0i}(U, t)/n_{ei}(t)$ of the electron velocity distribution function normalized on the electron density $n_{ei}(t)$ for the discharge re-

gions $i = 1$ (full line) and $i = 2$ (dashed line) is shown for several instants of the temporal evolution. During the low- and the early high-current phase the distribution functions in both regions almost coincide. Then the population of the distribution at higher energies diminishes in region 1 compared with the corresponding population in region 2. The behaviour of the distribution functions is accompanied by a different evolution of the corresponding electron transport coefficients and rate coefficients for electron-heavy particle collision processes in both discharge regions. Thus, the commonly used simplified treatment in the literature describing the reaction kinetics by transport and rate coefficients, which are tabulated as a function of the reduced electric field strength only and are related to hydrodynamic stages, may cause misleading results.



Similar results have been obtained for a variety of discharge parameters. In general it has been found by the parallel resistor calculations, that even small density perturbations of preionization electrons lead to the constriction of the discharge to the region with the initially higher electron density. The development of an inhomogeneous discharge plasma and laser output occurs faster, if the magnitude of the electron density perturbation and the HCl portion of the gas mixture are increased and the cross section area of the discharge region with higher initial electron density is decreased. On the other hand, the stabilizing effect of the low-current discharge phase for the discharge operation found in experiments was not explicable by the model.

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Exploring the influence of ambipolar diffusion mechanism in a Hg-Ar low pressure positive column under AC operating conditions by a self-consistent time-dependent collisional-radiative code

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1. Introduction

Lots of experimental and theoretical studies concerning low pressure mercury-argon discharge exist. The main application of such studies deals with lighting domain, in particular with the fluorescent tube that is a specific low pressure mercury-argon discharge. The last few years, important progresses, concerning not only the increase of light efficiency but more generally better knowledge about gas discharge behaviour, have been achieved. These researches mainly turn to more and more complete models which allow the prediction of optimal operating conditions of lamps. Thus, better understanding of important mechanisms taking place in the system is accomplished as well. The aim of modelling of Hg-rare-gas low pressure discharge lamps, which is a necessary complement to experimental investigations, is to predict the optimal operating conditions of these devices. Optimal operating conditions, in the case of certain applications, mean high luminous intensities at selected wavelengths and high efficacy for a large range of ambient temperatures. These operating conditions depend closely on several external parameters such as tube diameter and shape, discharge current and partial pressures of mercury and rare-gas in the positive column plasma.

This work deals with use of a collisional-radiative model concerning low pressure mercury-argon discharge operating under AC power supply in order to explore the positive column behaviour in a large domain of operating frequencies.

2. The model

This Self - Consistent Time - Dependent Collisional - Radiative model allows the determination of various characteristic quantities of the discharge solving the population and electronic energy conservation equations coupled to quasi-neutrality condition, perfect gas law and Ohm's law. In order to treat effectively this equation set we need the following simplifying assumptions: The positive column is assumed to be axisymmetric and therefore all calculations have been performed using cylindrical co-ordinates.

In this model, we consider for Hg atom a six level scheme (6^1S_0 , $6^3P_{0,1,2}$, 6^1P_1 , 7^3S_1) and the mercury ion. In this work we include also a very simplified 3 atomic level for argon (Ar , Ar^* , Ar^+). As the average energy of

Ar^* atomic levels is about 11.65 eV direct ionisation from the ground state is assumed negligible under the conditions considered in this study (the mean electron energy is about 1-2 eV). Interactions such as quenching, associative and Penning ionisation have been taken into account.

In the low pressure discharges, a diffusion controlled positive column is frequently assumed (Schottky's regime). The main ion-electron loss process is the diffusion of these pairs on the tube wall where recombination takes place, rather than the volume recombination. However, all classic models accounts for ambipolar diffusion mechanism, unfortunately this is valid if only one type of ion is present in the plasma. In our case where Hg^+ , Ar^+ are existing we should use a more complete model to describe the charged particle diffusion as described by Rogoff [1].

The electronic temperature is assumed constant over the discharge tube radius. This assumption is justified experimentally by probe measurements [2]. We note that this hypothesis is rather restrictive and more especially in cases where total pressure increases or tube radius decreases.

3. Results

In this paper we focus our interest on the positive column behaviour of an almost classic fluorescent lamp a function of the applied frequency (AC power supply) and for two different buffer gas pressures. Thus calculations are performed for a discharge with the following characteristics:

Discharge internal radius $R=14$ mm
Hg pressure $p_{Hg}=6.3$ mTorr
Buffer gas pressure p_{Ar} : 3 and 5 Torr
Arc current form $I(t)=I_0\sin(2\pi ft)$
Current amplitude $I_0=400$ mA
Frequency range f : 50 Hz up to 100 kHz

We note that the chosen mercury pressure correspond to a cold spot temperature of about 40°C which is very close to the maximum emission conditions for the 254 nm radiation.

Figure 1 illustrates the calculated electron temperature as function of frequency for two buffer gas pressures.

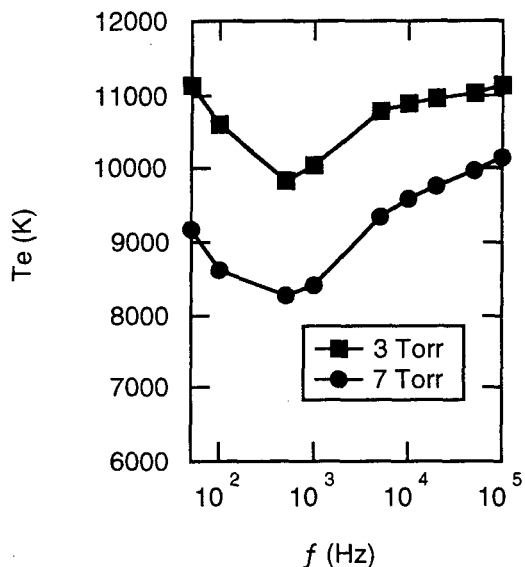


Figure 1

We observe that electron temperature presents a minimum (for both buffer gas pressures) in a frequency value of about 500 Hz. This minimum corresponds to a peculiar value linked to characteristic time of ambipolar diffusion in the positive column ($\tau_{amb} \sim ms$). This limiting frequency value could be observed also in the figure 2 which presents the arc voltage wave form during a half operating AC period.

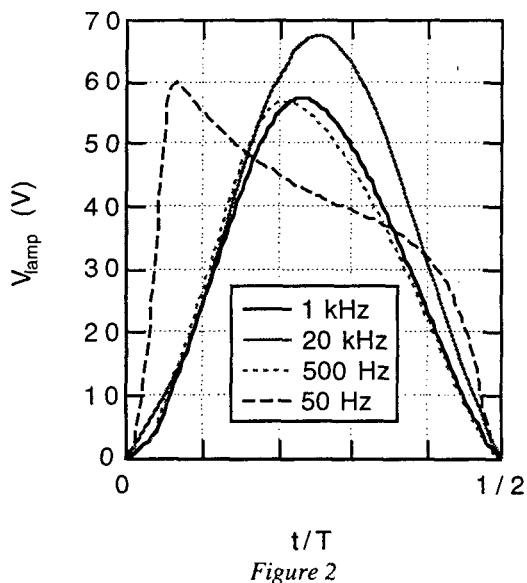


Figure 2

We observe that the wave form changes fundamentally in the region of 500 Hz. In fact, for frequencies larger than this limiting value the ratio of odd higher rang voltage harmonics (3, 5...) decreases very rapidly. An other important point is the following: Electron temperature is lower in the case of higher buffer gas

pressures for any frequency value. This behaviour could be explained by considering fact that when pressure increases, elastic collision energy loss increases too. Figure 3, confirms the previous explanation by illustrating the calculated electron density as function of ac frequency. As we observe, on the one hand, electron density increases when buffer pressure grows. On the other hand, electron density remains almost constant in the overall frequency range studied here.

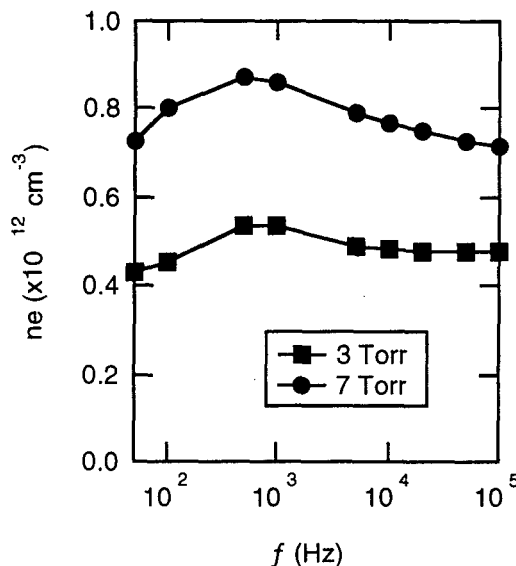


Figure 3

Finally, our calculation show that electric field values in the positive column pass through a minimum value in the same characteristic frequency. However, the overall UV efficiency remains almost constant (within $\pm 2\%$) for a large frequency range within the studied domain.

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Power interruption experiments on a high pressure sulphur discharge

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1. Introduction

Power interruption experiments have been performed on a high pressure sulphur discharge sustained by microwaves. Such experiments involve the switching off of the power applied to the plasma and observing the responses in the spectrum. The spectrum of the discharge is continuous. The turn off time is typically 100 μ s at a repetition frequency of 40 Hz.

The plasma responds instantaneously to the removal of power indicating that it is not in LTE and that the electron temperature probably is significantly greater than the heavy particle temperature. It is expected that the difference in electron and heavy particle temperatures will be significantly greater than that normally observed in high pressure discharges. During the power off period a gradual response was observed.

2. Background

The spectrum of such a discharge is shown in figure 1. The plasma is very weakly ionised (ionisation degree ca. 10^{-4}) and no sulphur atomic lines have yet been observed. It is expected that this absence is due to inverse predissociation of sulphur and also to selective optical thickness of the molecular species to these lines. A backfill of argon is used as an aid to ignition but also its presence is essential to the processes that produce the spectrum.

As yet no argon lines have been search for.

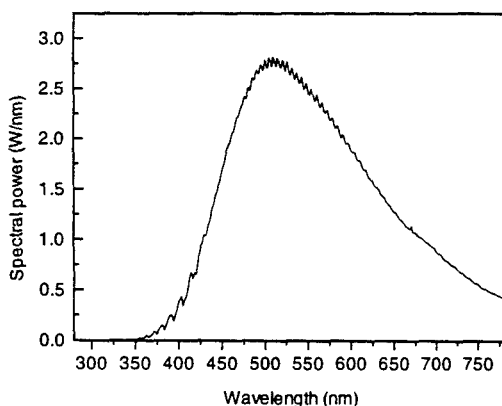


Figure 1: Spectrum of a microwave sulphur discharge

3. Processes

The spectrum depicted in figure 1 appears continuous however this due to the significant pressure broadening of vibrational lines. Any rotational transitions are 'washed' out of the spectrum. The potential curves of sulphur are described in figure 2.

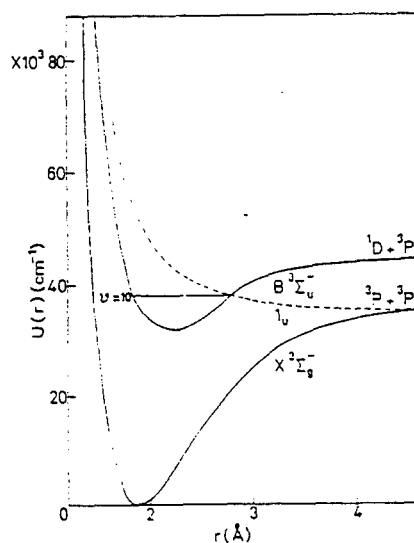
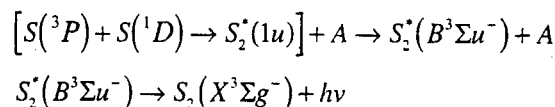


Figure 2: Potential energy curves of S_2

The reaction that drives this process is believed to be



Where A is most likely an argon atom (the density of atomic sulphur is sufficiently smaller) which in the collision carries away such amounts of energy as to populate all the vibrational levels with $v' \leq 9$ of the B state of S_2 which in turn will give rise to the observed spectrum.

With such a process atomic sulphur lines should be expected, however none have been observed, even in low pressure discharges. With knowledge, a priori, of some processes the structure of the plasma can be determined.

The beauty of the power interruption technique is that it allows investigation of the hierarchy of balances in the plasma.

Measurements on a high current conventional fluorescent lamp and comparison with the numerical model

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1. Introduction

There is an increasing interest in electrodeless lamps as, amongst other reasons, the life time is considerably longer than the conventional discharge lamps. Furthermore, reactions between the electrodes and the plasma are avoided, which makes the choice of the filling less restricted.

One special class of electrodeless lamps are the inductive fluorescent lamps. The first commercial lamps in this class have become available: the QL-lamp of Philips since 1992 (cf. Figure 1) and the Genura of General Electric since 1994 [1]. Recently Osram Sylvania announced the Endura. With respect to the mechanism of light generation these lamps are similar to the common mercury fluorescent lamp. Inside mainly UV radiation is created which is converted into visible light by a fluorescence powder situated at the wall of the bulb [2,3]. Besides the lack of electrodes, the other main difference between the electrodeless and the conventional fluorescent lamps is the plasma current. A typical current in a conventional fluorescent lamp is 400 mA, which is much lower than that in the inductively coupled lamp: 5 to 10 A.

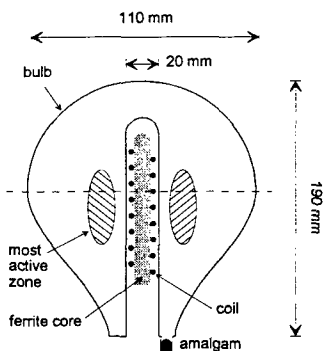


Figure 1: A schematic of the Philips' QL-lamp.

At the Eindhoven University of Technology a model is being developed which describes the QL-lamp. This two-dimensional model is also presented at this conference [4]. Based on the design parameters, like the driving current and gas pressures, macroscopic quantities as the production of light and heat are calculated. This model basically consists of two parts: one describing the gas discharge and an other describing the coupling between the coil and the plasma. The discharge physics differs from that used in models on the more conventional fluorescent lamp (as for instance [5]), since due to the much higher plasma current it is expected that the electron density is much

higher. This means that step-wise excitation has to be taken into account [6].

In this contribution measurements are presented which are used to verify the gas discharge model.

2. Experiments

In order to check the validity of the gas discharge model the voltage-current characteristics of several linear discharge lamps have been measured. The configuration is the same as the common fluorescent lamps, but the operating parameters are similar to those of the QL-lamp. Special electrodes are used in order to be able to operate at currents between 5 and 15 A. The radius is taken equal to the distance between the center of the most active zone and the inner wall of the bulb (see Figure 1), which is approximately 1 cm [7].

The voltage-current characteristics have been measured as function of the argon and mercury pressures, the kind of noble gas filling and the radius of the discharge tube.

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Topic 19a

Special topic at the XXIII ICPIG :
Highly ionized, low pressure plasmas
(plasma thrusters, ion sources
and surface treatment).

A diffusion model for near wall conductivity in plasma thrusters

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We propose a macroscopic diffusion model to describe the near wall electron conduction in plasma thrusters. For isotropic scattering, analytic diffusion and conductivity coefficients are obtained, which are inversely proportional to the square of the magnetic field, as experimentally observed.

1 The Stationary Plasma Thruster

Our model is aimed at describing the electron distribution function in an SPT 100 engine (see [2] for the operation principle of the SPT 100).

See figure 1 for a geometrical description.

2 Derivation of the Model

We start with the free transport equation on the electron distribution function in dimensionless variables:

$$\frac{\partial f}{\partial t} + v \cdot \nabla_x f + (E + v \times B) \cdot \nabla_v f = 0$$

$f(x, v, t)$ being the electron distribution function, $E = E_z \vec{e}_z$ is an axial electric field, $B = B_r \vec{e}_r$ is a radial magnetic field.

The boundary conditions are modelled by a splitting into specular and diffusive reflexions. The latter are then splitted into elastic and inelastic parts, given by integral operators. For the outer cylinder $f_-(v) = f(v)|_{v_r < 0}$ is the part of f outgoing from the boundary, and $f_+(v) = f(v)|_{v_r > 0}$ is the incoming part of f (for the inner cylinder the signs are

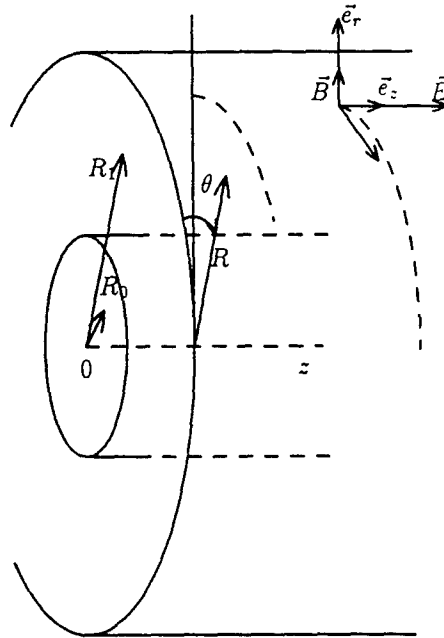


Figure 1: geometry and notations

reversed), and the reflexion operator reads:

$$\begin{cases} f_-(v) = \\ \alpha f_+(v^*) + (1 - \alpha)((1 - \beta)\mathcal{K}(f_+) + \beta\mathcal{H}(f_+)) \quad (2) \\ \text{with } v^* = (-v_r, v_\theta, v_z) \\ \mathcal{K}: \text{elastic part of the diffusive reflexions} \\ \mathcal{H}: \text{inelastic part of the diffusive reflexions} \end{cases}$$

\mathcal{K} is given by an integral operator:

$$\mathcal{K} f_+(v) = \int_{\{\omega' \in S^2, \omega'_r < 0\}} K(z, |v|, \omega, \omega') f_+(|v|\omega') d\omega' .$$

$\forall v \in \mathbb{R}^3, v_r > 0,$

where the velocity direction $\omega = v/|v|$ belongs to the unit sphere S^2 and the kernel K satisfies some properties.

$\alpha \in [0, 1]$ is called the accommodation coefficient. It represents the probability of a specular reflexion, $1 - \alpha$ is thus the probability of all other events, that is to say the diffusive reflexions. $\beta \in [0, 1]$ is the probability of an elastic reflexion among diffusive reflexions, $1 - \beta$ of the inelastic reflexions among diffusive reflexions.

The model is based on the assumption that the distance between the two cylinders $R_1 - R_0$ is smaller than the radius of the cylinders R_0 . We introduce a small parameter $\eta = \frac{R_1 - R_0}{R_0} \ll 1$.

The equations are then properly scaled.

When η is very small, under fairly general conditions on the elastic scattering operator, we get at leading order:

$$f_0(x, v) = N(z, \varepsilon = |v|^2/2, t) \quad (1)$$

where N satisfies a diffusion equation in the $(z, \varepsilon = |v|^2/2)$ space, which reads:

$$\sqrt{2\varepsilon} \frac{\partial N}{\partial t} + \left(\frac{\partial}{\partial z} - \bar{E} \frac{\partial}{\partial \varepsilon} \right) \cdot \bar{J} = Q(N) \quad (2)$$

$$J = -D \left(\frac{\partial}{\partial z} - \bar{E} \frac{\partial}{\partial \varepsilon} \right) N \quad (3)$$

$Q(N)$ depending on the inelastic part of the reflexion operator.

The diffusion coefficient admits an analytical expression in the isotropic scattering case:

$$D(B, \varepsilon) = \frac{\varepsilon^2 \beta}{B^2} \int_0^1 G(B, \varepsilon, w) w(1-w^2) dw$$

with γ and β constant terms and

$$G(B, \varepsilon, w) = \left(1 - \cos \frac{B}{\sqrt{2\varepsilon} w} \right)^2 + \frac{\gamma}{\beta} \sin^2 \frac{B}{\sqrt{2\varepsilon} w}$$

3 Second order Boundary Conditions

To account for the electrons leaving the device at the cathode or absorbed by the anode, a Robin boundary conditions is set up:

$$f - \Lambda \cdot \eta \frac{\partial f}{\partial z} = f_0$$

where the extrapolation length Λ can be approximated in a first step by (the sign of Λ is positive for the anode and negative for the cathode):

$$\Lambda = \pm \frac{D(B, \varepsilon)}{2D}$$

4 Scattering

The dominant scattering process is the collision with the boundary, modelled by (2). However Coulomb scattering against ions may be non negligible. An approximation for these scatterings will be included in the numerical computation.

5 Numerical Results

Numerical work is in progress. We will give a comparison with computations by a Monte Carlo method (see [3]).

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OPTICAL AND ELECTRICAL INVESTIGATIONS ON PLASMA OSCILLATIONS OF SPT THRUSTERS

- ABSTRACT -

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1

INTRODUCTION

Oscillations in Stationary Plasma Thrusters (SPT) seem to play a major role in the good working of the thruster. However, these instabilities have to be controlled for the integration of the SPT on board and for Power Processing Unit (PPU) design. A better understanding of oscillations is essential for future improvement of SPT, PPU and FU (Filter Unit) designs. In this paper, we will describe oscillations of light intensity emitted by the plasma, corresponding to the local fluctuations of excited species densities. Then, we will analyse the electric behaviour of the system PPU / FU / SPT.

SETUP

Measurements were performed on a SPT thruster, in the SEP test facility. The thruster worked in nominal conditions (4.5 A, 300 V, 5 mg Xe/s) in the 13 m³ cryogenic pumping tank at a working pressure of 5 10⁻³ mtorr of xenon. Data correspond to a thruster lifetime of 800 to 1300 hours.

The optical image of the exit plane of the thruster is realised with a spherical mirror (see figure 1). The light is collected by two optical fibres whose positions are moveable on X (horizontal) and Y (vertical) axis. The detection consists of two photo multipliers. The collected light come from a quasi cylinder of plasma (0.5 mm diameter). The 45 deg. angle between thruster axis and optical axis allows observations inside the channel.

Current and voltage probes have been inserted to measure electric signals at characteristic points of the electric circuit (figure 2). Different values of Rf, Cf and Cx have been tested.

This setup allows the characterisation in space, time and frequency of the light emission and give the evolution of electric oscillations as a function of FU parameters

OPTICAL MEASUREMENTS

Description of oscillations

By a spectral analysis of the collected light, we can identify three groups of oscillations :

- A sharp peak at about 33 kHz, followed by 3 to 4 harmonics,
- A wide band, which shut down at about 200 kHz,
- A wide band, in the range of 200 - 500 kHz.

Oscillations at lower frequencies than 10 kHz are not available due to the spectrum analyser.

Oscillations at higher frequencies than 1 MHz imply only electrons, so they are not measurable with this method.

The optical signal, read on a time scale reveals a strong periodicity at a frequency of 33 kHz (about $\pm 70\%$ of the total light intensity), a not symmetric signal (peak of intensity followed by a longer silent period) and the presence of an anomaly (little spike called "Vestnik" in Russia), decorrelated with the main oscillation.

Behaviour of the plasma

By measuring phase shift between two signals (corresponding to different points of observation), it can be concluded that the oscillation is propagating along the thruster axis, with a velocity of about 20 km/s. This result leads to the idea of a periodic ejection of ions at the frequency of 33 kHz. Moreover, observation of light emitted in the plume shows that we have a pulsed ejection (<10 μ s) of ions followed by a silent period (20 μ s).

Measurements of DC magnitude of light intensity and RMS level of oscillation as a function of the observed position can be interpreted in term of motion of the emissive zone. This have been checked with a simple numeric code. Making some assumptions, the model calculates the DC and RMS profiles of the light intensity which would be measured in our experimental conditions for different forms and different motions of the emissive zone.

The best similitude between measurements and calculations occurs for a pulsating plasma ring whose section is represented on figure 3 & 4). The calculation find a radial and axial motion. The minimum of light intensity corresponds to a thin emissive zone (figure 4). In opposition, the maximum corresponds to a wide luminous area (figure 3).

ELECTRIC MEASUREMENTS

Oscillations in nominal working conditions

The discharge current (Id, figure 7) shape is about the same as the optical signal one. The magnitude of the 33 kHz oscillation is ± 3 A.

An oscillation of ± 3 V is measured on the discharge voltage (Vd). Based of Id and Vd signals, the impedance "seen" by the plasma has been calculated in the range 0 Hz - 1 MHz. The result fits very well with an impedance calculation of the complete electric circuit. We can identify the respective influence of each component as a function of an increasing frequency : Output impedance of PPU, Magnet coils, Cf, induction of wires. For the 33 kHz oscillation, the impedance of PPU + FU is reduced to the capacity Cf. That is why a parametric test on Cf has been performed.

A common mode current (difference between anode and cathode currents) has been detected. We find a wide band (~ 10 kHz - 1 MHz) and a 33 kHz component. This circulation of AC current, which can reach 200 mA RMS, is made possible through parasitic elements, looped by the vacuum chamber structure. This has been characterised by the addition of a capacity between the cathode and the tank structure (Cx).

Influence of FU parameter changes

- When Cf is lower than a critical value (~ 0.5 μ F), we can observe a decrease of the thruster efficiency, coupled with a slight decrease of Id oscillations and an increase of the common mode current. In this case, the impedance seen by the 33 kHz is not capacitive, but ruled by inductive elements.

- An increase of the capacity Cf leads to a decrease of discharge voltage oscillations, whereas current oscillation magnitude is not affected by this change. We can conclude that at the frequency of 33 kHz, the plasma is equivalent to a perfect current generator, which has to be loaded by a capacity.

By the study of common mode currents and cathode floating potential, it has been shown that the common mode current flows mainly through the parasitic capacity between the cathode and the tank structure (Cx). With a low value of Cx (10 nF), the common mode current can be strongly attenuated (< 50 mA RMS), although high frequency oscillations persist.

CONCLUSION

Measurements of plasma luminosity has allowed a characterisation in time and space of the excited species density, which is equivalent to the plasma density.

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The relative stability of the 33 kHz oscillation, a high harmonic content and the richness of the spectrum up to 500 kHz have been highlighted. The profiles of DC and oscillating levels have made possible a reconstruction of the emissive zone shape. Moreover, a pulsating mechanism of the plasma and a pulsed ejection of ions have been suggested. Electric measurements reveal that the plasma is equivalent to a current generator oscillating at the frequency of 33 kHz in a capacitive load. Anyway, the electric response of PPU + FU to this current stimulation can be understood only by a complete circuit analyse, including in particular parasitic elements, impedance of power supplies and capacitive effects with the chamber.

ACKNOWLEDGEMENTS

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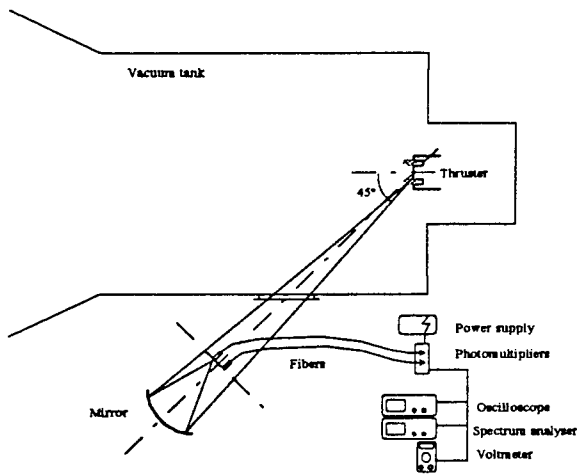


Fig. 1 : Schematic of the setup

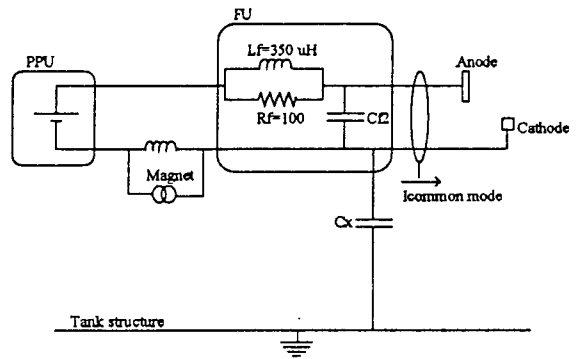


Fig. 2 : Simplified electric circuit

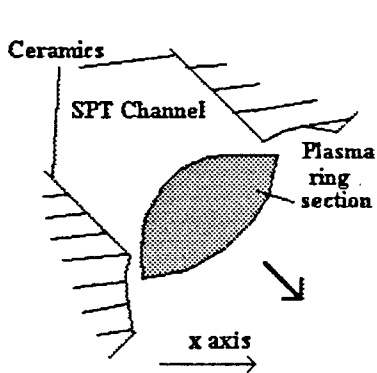


Fig. 3 : Plasma ring section (optical signal = max)

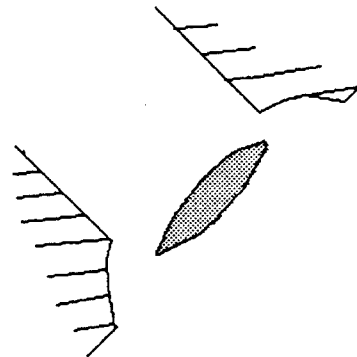


Fig. 4 : Plasma ring section (optical signal = min)

SPT as gas-discharge device.

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It is known that classic discharges (arc, glow, etc.) was investigated during nearly 200 years in several countries. Physical processes in these discharges are studied sufficiently well and theory coincides with experiment. Their main features are well known: the presence anode and cathode (source of electrons) between which a voltage is applied, the main voltage drop taking place near a cathode and just here being the main ionization region, electric field in plasma column being less by several orders than in near-electrode zones and practically whole discharge current being transferred by electrons (positive ions only compensate spatial charge of electrons). Besides, plasma ionization degree is very small in such discharges and ionization processes is not by the drift velocity along the field but by high random velocities which obtained as a result of numerous elastic collisions in electric field. Electron distribution in these discharges is close to maxwellian with temperatures, usually, up to several electronvolts (.1 - 10 eV). Dielectric walls restrict discharge and ion flow reflected from the walls equals zero.

SPT as the discharge device (Fig.1) has many features similar to classic discharge: there are a cathode (electron source), an anode, dielectric chamber which restricted discharge. But magnetic field transversal to electric field exists in SPT. This circumstance changes the situation in principle. The applied magnetic field increases from the anode to the cathode and is maximal near system outlet. Its magnitude is chosen so that electrons in the region where magnetic field is near maximum electrons are magnetized and ions are not magnetized (the Larmour radius of latters is much greater than system size). The characteristic feature of electric potential distribution in such a system is a presence of overthermal electric field which magnitude is determined by dynamics of electron component

$$\vec{E} = -\frac{\nabla p_e}{en} - [\vec{v}_e \vec{B}].$$

Projection of this equation on the magnetic field direction gives

$$-e \frac{\partial \phi}{\partial l} + \frac{kT_e}{n} \frac{\partial n}{\partial l} = 0$$

which means

$$\phi - \frac{kT_e(\gamma)}{n} \ln \frac{n}{n_0} = \phi^*(\gamma).$$

Here n_0 is arbitrary constant. We call $\phi^*(\gamma)$ as "thermalized" potential. It remains constant along magnetic force line $\gamma = \text{const}$. That is, magnetic force lines are equipotential and the change of ϕ^* due to

displacement from one magnetic surface to another is set by either special electrodes or by the conductivity of plasma flow. This conductivity can be "classic" (collisions of electrons with heavy particles, ions and atoms), "anomalous" (electron scattering on fluctuations and oscillations) and "near-wall" (diffusive scattering of electrons on accelerating channel walls). Experiments revealed that electron scattering transfer due to oscillations is $\sim 10\%$. In the region where electrons are maximally magnetized the transfer is realized by collisions. But from ionization zone to near-anode zone the transfer is realized by near-wall conductivity. The mechanism of near-wall conductivity forecasted by A.I. Morozov [1] may be considered as classic stipulated by diffusive collisions with "big molecule", that is with wall. Such collisions lead to the loss of electron drift velocity. When electrons restore their drift velocity they move opposite electric field and increase their kinetic energy, that is are accelerated. Electrons move inside plasma volume along cycloida-like trajectories. As a result, plasma volume is divided into layers having alternated directions of electric current. Since electron flow falling on the walls is nonmonochromatic the distribution of electric current is oscillating (Fig. 2).

Electron distribution in SPT is nonmaxwellian. Its characteristic shape (Fig.3) is determined by the presence of dielectric walls and volume electric field. Mainly, near-wall fields separate the group of long living electrons rotating azimuthally as a solid body, at first approximation. The second group of electrons is so called "runaway" electrons which take part in near-wall conductivity. These electrons move opposite electric field increase their energy proportionally with passed voltage. The third, intermediate, group exists between these two main groups. Intermediate electrons collide inelastically with the wall and pass continuously from one group to another.

The change of main plasma parameters (n_e , T_e , ϕ) in the channel is nonmonotonous but has maximum near maximum of magnetic field. Maximum of electron temperature is nearer to the anode than density maximum which can be explained so that the main flow on ionization placed in the zone of magnetic field maximum. It is characteristically that maximum of T_e is determined by the value of first threshold of multiplication in energy dependence of secondary electron emission coefficient for wall dielectric. For dielectrics used in SPT this threshold is about 20 eV. Such high energy of electrons stimulates some unexpected phenomena: disruption of Debye layers from dielectric walls and anomalous erosion. The first phenomenon leads to oscillations of electron temperature in the discharge with maximal value ~

100 eV. The second one leads to appearance of clearly visible periodical structure oriented along channel axis [2,3].

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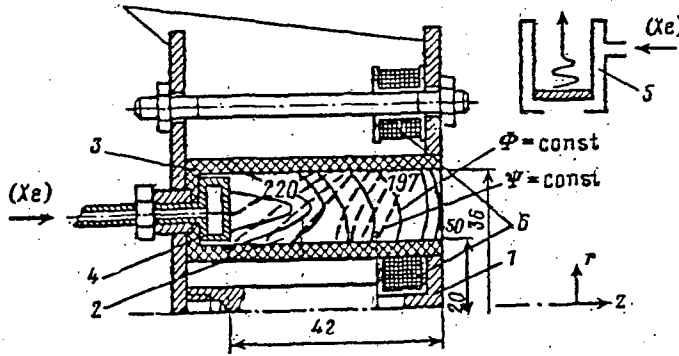


Fig. 1. Experimental SPT. 1 - magnet circuit, 2 - accelerating channel, 3 - dielectric channel, 4 - anode, 5 - cathode, 6 - magnetic coils.

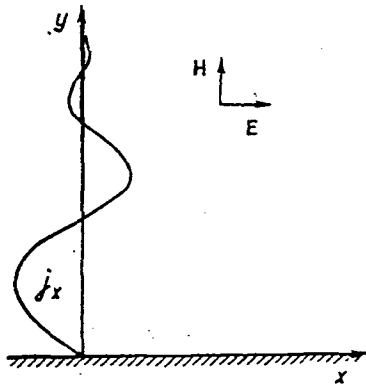


Fig. 2. Near-wall current density distribution.

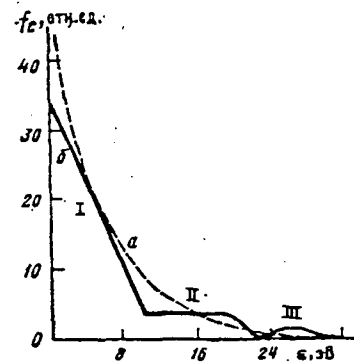


Fig. 3. Maxwell function (a) and electron distribution function (b) in SPT channel. I - closed electron group, II - intermediate group, III - runaway electrons.

One-dimensional Models of Stationary Plasma Thruster

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1. Introduction

A stationary plasma thruster (SPT, or Hall Thruster) is an electromagnetic thruster whose properties make it especially suitable for applications such as satellite station-keeping. Fig. 1 represents schematically the geometry of the SPT. Xenon is injected from the anode (rate on the order of 5mg/s), at the end of the dielectric cylinders and on the cathode side, outside the cylinders. We are mainly interested here in the plasma column which is located between the coaxial cylinders (internal radius: 3 cm, external radius: 5 cm). Since the device must work under conditions of relatively low gas density (the xenon density is on the order of a few 10^{13} cm⁻³ close to the anode), and the length of the column is on the order of a few cm (typically 4 cm), the electrons undergo very few collisions from the cylinder entrance, on the cathode side, to the anode and it would not be possible to sustain a plasma in the column without enhancing the confinement of the electrons. This confinement is provided by a magnetic field created by coils which are located on the external surface of the cylinder. The magnetic field is radial in the exhaust region (cathode side of the cylinders), and on the order of 200 G at the exhaust and ten times less at the anode). The potential drop in the plasma column can be as large as 200 to 300 V in standard conditions.

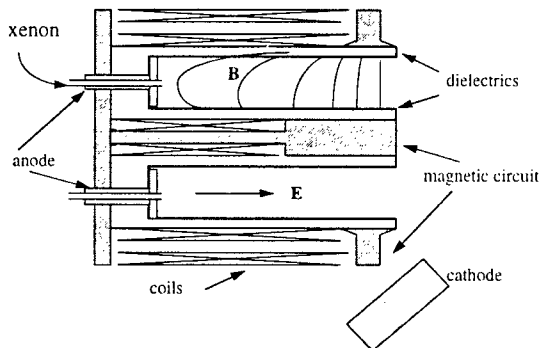


Figure 1: Schematic of the SPT geometry.

2. Physical description

Several features of the SPT are not well understood. One of them is the conductivity of the column which is much higher than what could be expected from the classical collisional conductivity in a transverse magnetic field. The collisional electron mobility perpendicular to a magnetic field line is given by:

$$\mu_c = \frac{e}{mv} \frac{1}{1 + \frac{\omega_B^2}{\nu^2}} \quad (1)$$

where ν is the electron collision frequency and ω_B the electron cyclotron frequency $\omega_B = eB/m$.

Assuming an electron mobility of this form, the order of magnitude of the current flowing through the device can be estimated by $J_T \approx en\mu_e E$ where n is the plasma density and E the electric field in the column. The Plasma density and electric field in the column can be estimated from experimental measurements and are on the order of 10^{12} cm⁻³ and 50 V/cm, respectively. Calculating the current from this estimation of the plasma parameters and mobility gives the results represented in Fig. 2.

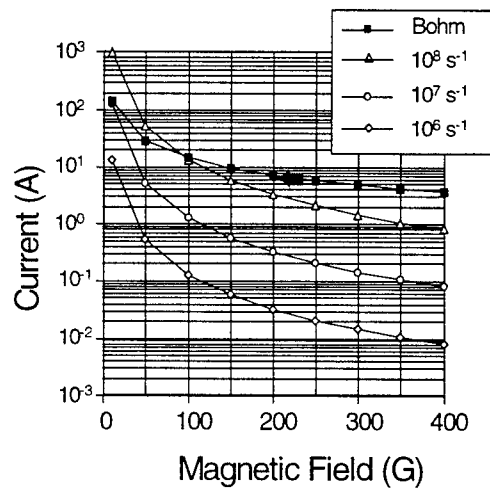


Figure 2: Estimated current in a SPT for typical conditions and different values of the electron collision frequencies using a classical mobility (open symbols - Eq. 1), and assuming anomalous Bohm conductivity (full symbols). The arrow represents a typical current measurement under these conditions.

The typical electron-neutral collision frequency in the SPT is in the 10^6 - 10^7 s⁻¹ range and is much too small to be responsible for the large measured conductivity. Assuming [1] anomalous Bohm conductivity (i.e. conductivity due to field fluctuations, with an electron mobility of the form $\mu_c \approx \frac{1}{16B}$) gives a current in better agreement with experimental measurements. However it has not been clearly established that Bohm diffusion plays an important role in this device and the Russian

school of Morozov *et al.* have proposed another interpretation of the observed anomalous conductivity [2]. They point out that electron collisions with the dielectric walls and secondary electron emission by electron impact could be responsible for the observed conductivity. The collisions frequency of electrons with the walls is on the order of 10^8 cm/s, which gives an electron mobility in the correct range - see Fig. 2. Other features of the SPT are far from being clearly understood. For example it seems that under standard operating conditions, the current through the plasma and voltage across the column undergo oscillations at frequencies from kHz to MHz with those in the kHz range being of large amplitude.

3. One-dimensional models

We have developed a simple 1D quasi-neutral hybrid model of the column. In this model the plasma is supposed to be quasi-neutral, i.e. the electric field distribution is not obtained from Poisson's equation but from a current equation. Ions are supposed to be collisionless and are described by a 1DIV (one dimensional in position and one dimensional in velocity) Vlasov equation with an ionization source term due to electron-neutral collisions. Electrons are supposed to be collisional and are simply described by a mobility limited current density, the mobility being the classical collisional mobility (taking into account collisions with walls) or a Bohm mobility. The electron energy distribution function is supposed to be Maxwellian and the electron temperature is given by a semi-empirical energy equation. The neutral atoms are all supposed to have the same velocity v_0 and to be lost in electron impact ionization events. A Monte Carlo simulation of the electron trajectories has been developed and can also be used to obtain a better estimation of the electron energy and ionization frequency [3].

The equations were solved for a steady state situation. Since this system is strongly non-linear the system was solved iteratively, using an underrelaxation method. Shown in Fig. 3 are the axial variations of the neutral and plasma densities for typical conditions of the SPT.

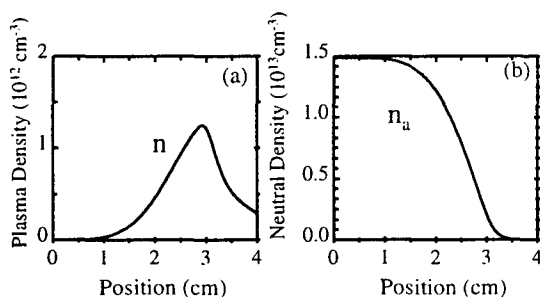


Figure 3: Axial variation of (a) plasma density, (b) neutral density.

The physical quantities obtained from the model are in good qualitative agreement with the measurements [4].

As mentioned above there is experimental evidence that large amplitude oscillations (20 kHz) of the current and voltage across the plasma column exist in the SPT even under normal operating conditions [5].

We have therefore looked for transient solutions of the set of equations described above. These transient solutions exhibit systematic oscillations at a frequency on the order of 100 kHz. The ion current displayed in Fig. 4 exhibits large amplitude oscillations in typical conditions.

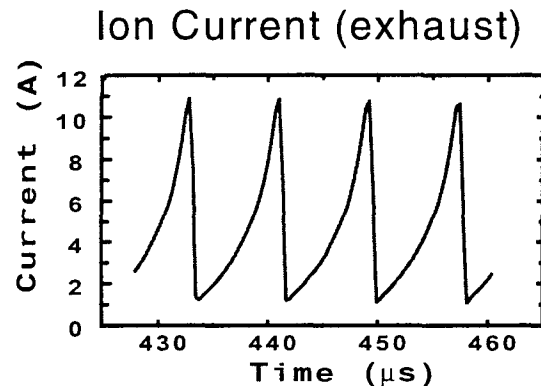


Figure 4: Time evolution of the ion current at the exhaust showing strong oscillations at a frequency on the order of 100 kHz.

4. Conclusion

Although more work is still needed to improve our understanding of the intricate physical mechanisms involved in a Stationary Plasma Thruster, some of the properties and characteristics of this device have been successfully (qualitatively) reproduced with simple models. Detailed comparisons with experiments will help us adjust and improve the assumptions of the models.

5. Acknowledgments

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Argon metastable density in Ar-O₂ and Ar-TEOS helicon plasmas.

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1. Introduction

The deposition of thin films by plasma generally involves mixtures of gases, which often contain an important fraction of argon. The important role of argon 1s₅ and 1s₃ metastable states which energy is 11.5 eV was demonstrated in different low pressure deposition processes [1,2]. Indeed they are able to dissociate or ionize the deposition precursors. Different experimental and modelling determinations of their density were recently developed. This study is devoted to the measurement of their density [Ar^M] in a low pressure helicon diffusion plasma created in Ar/O₂ and Ar/TEOS (tetraethoxysilane) mixtures. The variations of [Ar^M] as functions of the rf power and the oxygen fraction in Ar/O₂ mixtures will be investigated. Moreover we will try to measure if there is an efficient reaction between TEOS molecules and argon metastable states, or in other words if Ar^M are able to dissociate the TEOS molecule.

2. Experimental setup

The helicon reactor used for deposition of thin films from organosilicon vapor precursor is made of the helicon source and the diffusion chamber where the substrate is positioned and where most diagnostics of the plasma are carried out. A more complete description of the reactor can be found in [3]. In this study, plasmas are created in Ar/O₂ and Ar/TEOS mixtures. The total pressure and gas flow rate are fixed at 5 mTorr and 18 sccm respectively. The rf power is varied up to 400 W. The light emitted by the plasma is collected by an optical fiber at mid height of the diffusion chamber and analyzed by a HR 460 monochromator equipped with a 1200/mm grating and a Hamamatsu 928S photomultiplier.

3. Self absorption technique

The self absorption method [4] consists of measuring the ratio of two emission lines, which are self absorbed. There are two possibilities to choose the couple of spectral lines : either they decay on the same metastable state from upper levels with very different oscillator strength or they originate from the same upper level, one of them arriving on a radiative state, the other one on the metastable state. We have chosen the second approach, using the 800.6 nm (2p₆ --> 1s₄) and 763.5 nm (2p₆ --> 1s₅) Ar lines, where the 763.5 nm line is self absorbed. This choice allows us eliminate some populating effect when the plasma conditions change, because the two lines come from the same level.

This simple method can be used as long as the 800.6 nm line is not self absorbed, e.g. the density of the 1s₄ level can be neglected. Then the intensity ratio I_{763.5}/I_{800.6} is a function of K₀ℓ where ℓ is the optical depth in the plasma and K₀ is the absorption coefficient of the 763.5 line for a gaussian profile in a homogeneous medium. Finally the metastable density is given (in SI units) by :

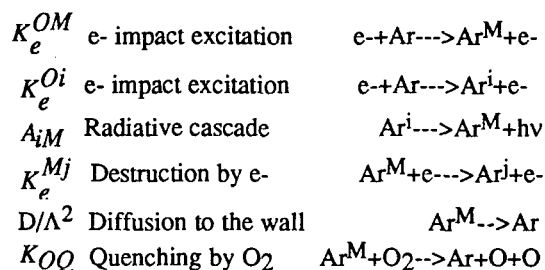
$$[\text{Ar}^M] = 1.363 \cdot 10^7 \frac{K_0 \sqrt{T}}{f \lambda}$$

where T = 300 K is the gas temperature, λ = 763.5 nm, and f denotes the oscillator strength.

4. Experimental results and discussion

In figure 1, the metastable density measured in pure Ar and different Ar-O₂ mixtures is plotted as a function of the rf power. As expected, whatever the rf power, the metastable density decreases as the O₂ fraction increases. This can be the consequence of different processes : the quenching of Ar^M by oxygen molecules, the decrease of Ar partial pressure, variations of the electron density. To circumvent the variations due to Ar partial pressure the metastable to ground state argon concentration ratio has been plotted in figure 2.

In order to further interpret these results we consider the following kinetics for Ar^M :



which yields the following relation :

$$[\text{Ar}^M] = [\text{Ar}] \frac{n_e (K_e^{OM} + \sum \frac{A_{iM}}{\sum A_{ij}} K_e^{Oi})}{n_e \sum K_e^{Mj} + [\text{O}_2] K_{OQ} + D/\Lambda^2}$$

First of all, let us note that the electron density increases with the rf power, typically ranging from a few 10⁹ cm⁻³ at 50 W to a few 10¹⁰ cm⁻³ at 400 W. Moreover, n_e is two times higher in Ar than in O₂ [3].

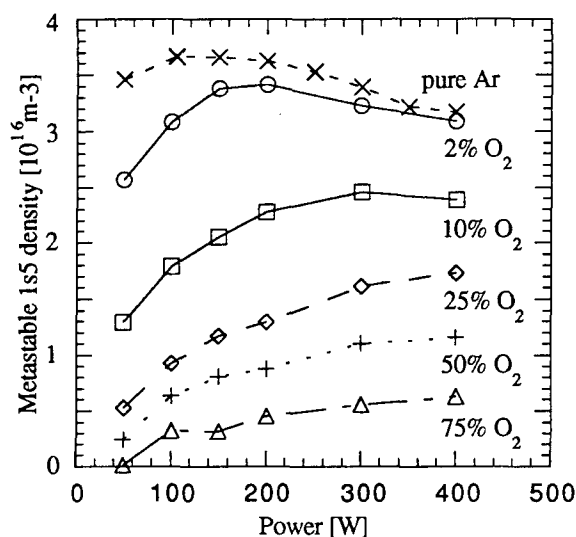


Fig. 1 : Metastable density as a function of the rf power.

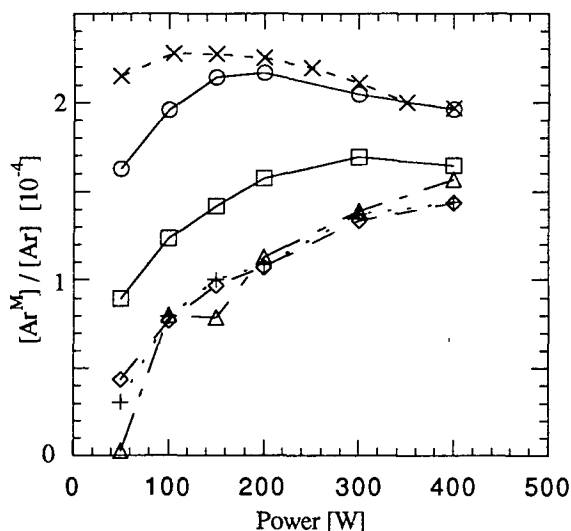


Fig 2 : Metastable density normalised to argon density (calculated at 300K) : same symbols as in Fig. 1

The first information given by figure 1 is that $[Ar^M]$ and n_e are of comparable magnitude. Second, from the above expression of $[Ar^M]/[Ar]$ two limit behaviours can be expected :

- (i) at low electron density (i.e. low rf power), as far as Ar^M is mainly lost by diffusion and/or quenching by O_2 , it is expected to be proportional to n_e .
- (ii) at high rf power it saturates at a limit value equal to the ratio of metastable production and destruction terms by electron collisions.

As can be seen in Fig. 2, the variations of $[Ar^M]/[Ar]$ are quite different according to the composition of the Ar/O_2 mixture. In pure argon the saturation limit is obtained from low rf powers. In contrast, in oxygen rich mixtures $[Ar^M]/[Ar]$ increases with n_e without reaching the saturation limit at 400 W.

This can be explained by the increase of the Ar^M loss by O_2 quenching which is never negligible as compared to the electron destruction term under our rf power range.

On the other hand, in the case of pure Ar, above 150 W, the metastable density decreases slowly as the rf power increases. Several interpretations are possible : an increase in the gas temperature with the rf power, a variation of the electron temperature or some error inherent to the simple absorption method used.

To investigate this latter point, the self absorption of the 800.6 nm Ar line was estimated. In fact if the density of $1s_4$ level becomes greater than $2 \cdot 10^{15} m^{-3}$, the 800.6 nm self-absorption can no longer be neglected. To take it into account the intensities of other Ar lines were measured. Three ratios are considered : I_{7635}/I_{8006} , I_{8014}/I_{8424} , I_{7067}/I_{7383} where the 763.5, 801.4, 706.7 nm lines arrive on the metastable $1s_5$ level and the 800.6, 842.4, 738.3 nm lines arrive on the radiative level. We just have to find a couple ($[Ar^M], [Ar1s_4]$) consistent with the three line ratios. The highest density of $1s_4$ radiative level is about $2 \cdot 10^{15} m^{-3}$, which validates the use of the simple method. Neglecting the 800.6 nm self-absorption only yields slightly underestimated metastable densities.

The other possible explanation of this decrease is that the EEDF changes above 150W, and loss processes with cold electron become greater. This might be consistent with the evolution of T_e measured by langmuir probes [3].

To conclude, the experimental variations of the Ar metastable density in Ar/O_2 mixtures are well described by a simple kinetic model. Further developments of this kinetic scheme are in progress.

In $Ar/TEOS$ mixtures preliminary experiments exhibit a decrease in $[Ar^M]$ as a few per cent TEOS is added to argon. The drops in $[Ar^M]/[Ar]$ measured in Ar/O_2 and $Ar/TEOS$ are of comparable magnitude. Further experiments and simulations are in progress in order to estimate the quenching rate of Ar^M by TEOS.

Conclusion

The argon metastable density has been measured in $Ar-O_2$ and $Ar/TEOS$ helicon reactors for different rf powers. By adding O_2 to Ar, a decrease in $[Ar^M]$ occurs due to their quenching by O_2 especially at low rf power. At high rf power their quenching by electrons seems to be higher than their quenching by O_2 .

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Emission spectra of O₂/TEOS plasmas used for SiO_xC_yH_z deposition

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1. Introduction

Plasmas of oxygen/tetraethoxysilane mixtures (O₂/TEOS) are widely used for the deposition of thin SiO_xC_yH_z films which are utilized as insulating, optical or barrier films. Although the properties of the deposited films have been investigated in the literature, very few studies were devoted to the plasma phase. Here we present the optical emission spectra of O₂/TEOS plasmas recorded in the 180-850 nm range. First of all the emission spectra recorded in a low pressure helicon diffusion plasma are studied as a function of the oxygen fraction in the O₂/TEOS mixture. Second, they are compared to the emission spectra from a DECR plasma.

2. Experimental

The low pressure rf helicon reactor used to create plasmas in mixtures of oxygen and vapour of tetraethoxysilane (Si-(O-C₂H₅)₄) is described in detail in [1]. It is operated a 2 mTorr, 300 W with a fixed total gas flow rate of 16 sccm. The light emitted by the plasma is transmitted to a 46 cm focal length monochromator (JY HR460) by an optical fibre positioned at mid height of the diffusion chamber. The monochromator is equipped with two gratings (a 2400 g/mm grating used in the 180-420 nm spectral bandwidth and a 1200 g/mm one used in the 420-850 nm spectral range), and a 928S Hamamatsu photomultiplier. The acquisition of spectra is monitored by a PC computer and the SpectraMax software. Under standard acquisition conditions the resolution was 0.3

nm, but resolution of 0.1 nm was achieved in order to identify unambiguously the multiple structures present in the emission spectra.

3. Emission spectrum

The spectra are dominated by the emissions of a few strong atomic lines or molecular systems but below these dominating features very complex structures can be observed. A typical spectrum of an O₂/TEOS plasma in the UV range which was seldom investigated, is shown in figure 1. Almost all the measurable features have been identified using the Pearse and Gaydon tables [2]. The emitting species depend on the oxygen content in the O₂/TEOS mixture. The main results are the followings :

(i) in an oxygen rich mixture, typically for an oxygen percent higher than 50 % all the identified structures can be attributed to CO, CO⁺, CO₂⁺, OH, O, H and C. Details on the corresponding transitions are given in table 1. Although relatively weak, seven systems of CO are unambiguously identified, most of them appearing in the UV range.

(ii) as the TEOS fraction is increased, the emission from oxygen atoms decrease, while new systems from CH, C₂ and H₂ appear.

(iii) in pure TEOS plasmas, the emission from oxygen atoms completely vanishes. The emission from H₂ is identified by a spectrum of isolated lines (denoted the secondary spectrum) in all the visible range, which

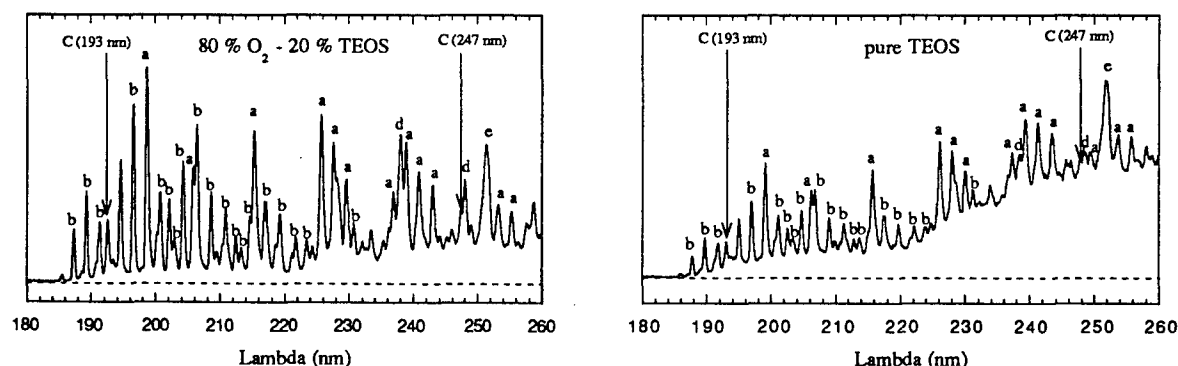


Figure 1 : UV Optical Emission Spectra (180-260 nm) of O₂/TEOS helicon plasmas created at 2 mTorr - 300 W letters a,b,c,e denotes the following systems of CO : a : Cameron bands, b : fourth positive system, d : 3A bands, e : Kaplan bands

	Transition	System name	Spectral range (nm)
CO	$A^1\Pi \rightarrow X^1\Sigma$	4 th positive syst.	180-255
	$a^3\Pi \rightarrow X^1\Sigma$	Cameron bands	206-258
	$b^3\Sigma \rightarrow a^3\Pi$	5B system	266-383
	$b^3\Sigma \rightarrow a^3\Pi$	3 rd positive syst.	283-370
	$c^3\Pi \rightarrow a^3\Pi$	3A bands	271-230
	$d^3\Delta \rightarrow a^3\Pi$	Triplet bands	401-647
		Kaplan Bands	275-252
		Ångstrom syst.	451-608
	$a^3\Sigma \rightarrow a^3\Pi$	Asundi bands	575-800
CO ⁺	$B^2\Sigma \rightarrow X^2\Sigma$	1 st negative syst.	219-255
	$A^2\Pi \rightarrow X^2\Sigma$	Comet-tail syst.	309-640
CO ₂ ⁺	$A^2\Sigma^+ \rightarrow X^2\Pi$	Bands $\lambda\lambda$ 2883	288.3
		and 2896	289.6
OH	$A^2\Sigma^+ \rightarrow X^2\Pi$	3064 Å syst.	281-309
CH	$A^2\Delta \rightarrow X^2\Pi$	4300 Å syst.	431.4
C ₂	$A^3\Pi \rightarrow X^3\Pi$	Swan syst.	516.5
H ₂		Secondary spect.	406-835

Table 1 : List of the molecular systems identified in the helicon O₂/TEOS plasma

are the strongest lines from the opened rotational structure of H₂. The most intense and isolated one appears at 752 nm. Moreover, as can be seen in figure 1-b some continuous emission appears between 200 and 300 nm, under the emission of the different systems of CO. This continuous emission is attributed to H₂ [3].

(iv) whatever the O₂/TEOS mixture and rf power, no emission from Si, SiO, SiH (which main lines or systems are expected at 288, 229.9 and 414.2 nm respectively) was seen. Similar observations were previously reported in different O₂/TEOS plasmas by several authors [4-6]. To our knowledge, Tochtani [7] was the only one to observe the silicon atomic lines at 288.1 and 254 nm in a low frequency discharge.

(v) although most of the structures are unambiguously identified, some of them could not be assigned to any emitting species : an example is a structure lying between 460 and 470 nm which appears whatever the TEOS fraction.

4. Comparison to the spectra emitted in a O₂/TEOS DECR plasma

The emission spectra of O₂/TEOS helicon and DECR plasmas are compared. In the DECR reactor the

emission spectra were recorded in the 240-500 nm range using a 32 cm focal length monochromator and a 1200 g/mm grating. Optical emission spectrometry was performed in pure TEOS and different O₂/TEOS DECR plasmas created at 1 mTorr, 200 W [4], e.g. under pressure and power conditions close to those of the helicon plasma.

The same species emitting in this reduced spectral range were identified in both spectra. The general trends relative to O, CH emission as a function of the oxygen content are quite similar. Nevertheless, the importance difference lies in the emission of CO⁺ ions : the CO⁺ Comet tail system is very intense in the DECR spectrum, whereas it remains very weak and mixed to neutral CO triplet bands in the helicon plasma. This difference certainly traduces the fact that the electron density in the DECR plasma is about 10 times higher in the DECR than in the helicon diffusion plasma (typically a few 10¹¹ cm⁻³ against a few 10¹⁰ cm⁻³ in pure oxygen plasmas).

5. Conclusion

In both reactors, the emission from CO and/or CO⁺ in pure TEOS plasmas suggests that CO is directly created by fragmentation of the TEOS molecule by electron collision. This is in pretty good agreement with the measurements by infrared absorption spectroscopy carried out in the DECR plasma, which prove the presence of stable CO and CO₂ molecules in TEOS plasmas [8]. In O₂/TEOS mixtures, CO and CO₂ are also formed from oxidation of the growing film by oxygen atoms. The absence of emission from any Si containing species is attributed to the fact that the Si-(O-C₂H₅)_n (n<4) fragments are incorporated into the growing film before all the Si-O bonds are broken.

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Helicon plasmas in various magnetic field configurations.

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1. Introduction.

The helicon radio-frequency sources provide the generation of high-density plasma at low pressure and relatively weak magnetic field. They have good perspective for application in plasma processing in submicron technology. Many experimental [1,2] and theoretical [3,4] studies have been devoted to the mechanism of high ionization efficiency and helicon wave absorption, but this mechanism still remains inconclusive. According to the theoretical investigations of helicon discharge the plasma density have to be sensitive to the magnetic field configuration. In the present paper we study the change over plasma characteristics at the formation of helicon waves for various configurations of magnetic field.

2. Experiment.

The plasma source consist of 15 cm in diameter and 40 cm long glass tube surrounded by two loops helicon antenna 17 cm long. Both are surrounded by two coils creating dc magnetic field. The diameter of coils is 24 cm, distance between them 25 cm. The tube is attached to the stainless steel chamber 26 cm in diameter and 25 cm in length. The chamber is surrounded by additional magnetic coil to reduce the divergence of magnetic field on the distance from the source. The rf (13.56 MHz) power is delivered by a 700 W generator and matching network.

The multy-grids electrostatic ion energy analyzer is used to measure the ion current and ion energy. Lengmuir probe is used for determination of plasma potential and electron density. Both are placed on the axis of diffusion chamber at the distance 30 cm from center of plasma.

Two configurations of magnetic field have been studied in our experiments. First-"uniform"-the magnetic fields of both coils are identically directed and create the axial and uniform magnetic field in discharge volume. Second-"trap"- the magnetic fields of two coils are contrary directed and create the configuration like to magnetic trap. The currents of magnetic coils in both magnetic field configurations are equal.

3. Experimental results.

The values of positive ion current I_p obtained in an Argon plasma at the pressure 3 mTorr are presented in figure 1. The curve 1 corresponds to capacitive mode of discharge in absence of magnetic field. The curves 2 and 3 represent behavior of I_p for "uniform" and "trap" configurations at the magnetic field value $H=30$ Gs. The curves 4 and 5 are the same at 60 Gs. One can see the passage from the capacitive to helicon discharge modes occur between 150 and 400 W of rf power. It depends

on value and configuration of magnetic field. This passage is indicated by the sharp increasing of I_p . One can see the values I_p for the "trap" configuration of magnetic field essentially exceed values I_p for the "uniform" configurations at the same values of rf power.

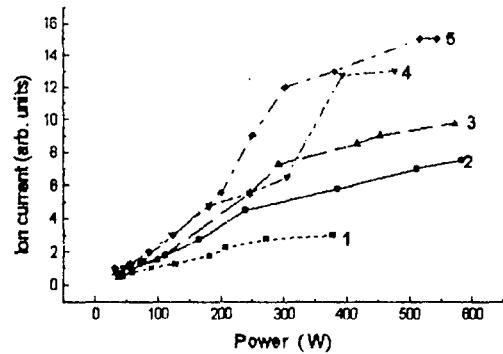


Fig.1 Ion current as a function of rf power: 1- $H=0$; 2,4-"uniform" configuration, 2- $H=30$ Gs, 4- $H=60$ Gs 3,5- "trap" configuration, 3- $H=30$ Gs, 5- $H=60$ Gs

Fig.2 shows the decrease of plasma potentials at the transition between capacitive and helicon discharges. It is clear the plasma potentials are the same for both magnetic field configurations after transition to the helicon discharge.

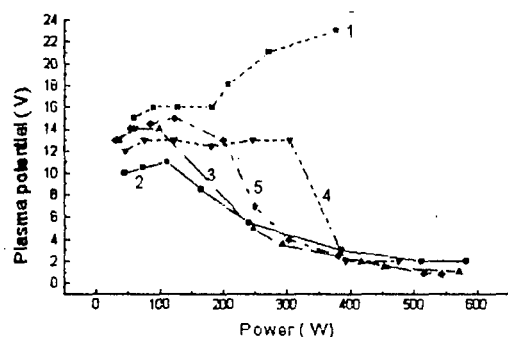


Fig.2 Plasma potential as a function of rf power. 1- $H=0$ 2,4- "uniform" configuration, 2- $H=30$ Gs, 4- $H=60$ Gs 3,5- "trap" configuration, 3- $H=30$ Gs, 5- $H=60$ Gs

Fig. 3 shows the variations of mean ion energy for both magnetic field configurations at $H=30$ Gs and $H=60$ Gs. One can see the ion energy increases sharply at the transition between capacitive and helicon discharge. After transition the ion energy at the "trap" configuration exceeds the ion energy at the "uniform" configuration of magnetic field.

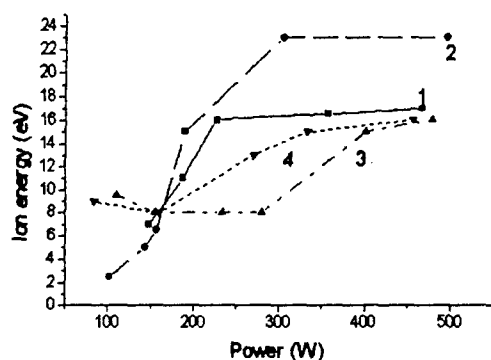


Fig.3 Ion energy as a function of rf power.

1, 3- "uniform" configuration, 1- H=30 Gs, 3- H=60 Gs
2, 4- "trap" configuration, 2- H=30 Gs, 4- H=60 Gs

The electron concentrations as a function of applied rf power is presented on figure 4. Electron concentrations increases at the transition between the capacitive and helicon discharge for both magnetic field configurations. After transition the increase of electron concentration terminates for "uniform" configuration, but keeps on for "trap" configuration.

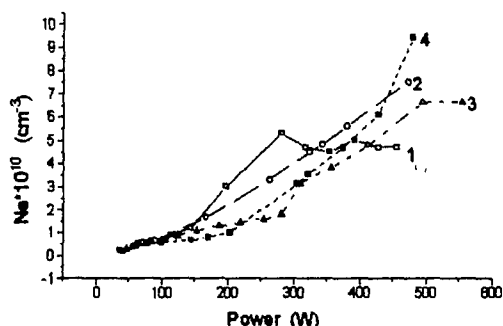


Fig.4 Electron density as a function of rf power.

1, 3- "uniform" configuration, 1- H=30 Gs, 3- H=60 Gs
2, 4- "trap" configuration, 2- H=30 Gs, 4- H=60 Gs

Radial distributions of ion current have been investigated for both magnetic field configurations and radial uniformity was similar in both cases.

4. Conclusion.

We have investigated the plasma parameters of helicon discharge in two essentially different magnetic field configurations. In "uniform" (axial and uniform magnetic field) the plasma parameters behavior is in agreement with the results of other investigators [1]. For example the sharp grows of plasma density at the transition between capacitive and helicon discharge terminates on some N_e (Fig. 4, curve 1,3). This N_e is approximately within the gap between N_{min} and N_{max} .

where the helicon waves at our magnetic field value and antenna length can exist [4].

In contrast for the "trap" (magnetic fields of coils are opposite directed) configurations the existence of helicon waves is doubtful at all. Nevertheless one can see the plasma parameters are the same ones in "uniform" configuration. However there is no termination of electron density growth after transition between capacitive and helicon discharge.

Notice that the ion current value and electron density in "trap" configuration exceed the ones in "uniform" configuration. So the "trap" configuration can be sometime preferable.

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Investigation of small, closed electron drift, SPT-50.

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I. INTRODUCTION

Recent work^{1,2} indicates interest in light controlled satellites, equipped with a low power electric thrusters. This work suggests that one of the most promising thrusters for these satellites can be the Hall-type thruster, which is widely used at present on satellites with 1 kW power on board³. The main advantages of the Hall-type thruster are the high thrust and energetic characteristics, an acceptable lifetime, simplicity and reliability of its design. In the meantime the first experiments with Hall-type (or stationary plasma thruster, SPT) of small power and also small size have shown that with the reduction of size the thrust and energetic characteristics go down considerably¹. The purpose of this work is to study the essential mechanisms in small size SPT in order to identify the main processes lowering the level of SPT characteristics when the thruster size is reduced, and optimize small SPT design. In an earlier work, we have studied a very small thruster SPT-20⁴.

II. THE TEST FACILITIES AND THE EXPERIMENTAL THRUSTER.

The SPT-50 thruster is studied in a test facility consisting of a horizontal, cylindrical stainless steel chamber (0.8 meter in diameter and 2 meters long). This facility is equipped with a cryogenic pumping system. Its pumping speed is 8000 l/s for air (with a residual gas pressure of 3×10^{-7} mbar). For a mass flow rate of 1 mg/s of the working gas (Xenon), the pressure in the chamber is 5×10^{-5} mbar.

Figure 1 shows schematically the experimental Hall-type thruster SPT-50 studied at Ecole Polytechnique. A coaxial discharge chamber is located in a magnetic field generated by the four outer and one inner coils. The main dimensions of the discharge chamber are: the outer diameter is 50 mm, the inner diameter is 28 mm and the distance between the anode and the channel exit is 25 mm. The magnetic system to produce an essentially radial magnetic field includes a soft iron magnetic circuit made of a back flange, and the two poles: the inner pole (a rod) and the outer, ring-shaped, pole. The gas, Xenon, is injected from the back end of the channel via a ring-shaped dispenser. The ring-shaped anode was fixed on the external ceramic wall of the channel. The cathode-neutralizer was a hollow cathode using LaB₆.

The structure of magnetic field has been studied using a Hall probe⁵. In the region of acceleration the obtained magnetic field has the typical for SPT lens-type structure. The magnetic field lines are not exactly

perpendicular to the axis, therefore the magnetic field is not purely radial, but has an axial component B_z . The maximum magnetic field B_r^{\max} is located just before the channel exit.

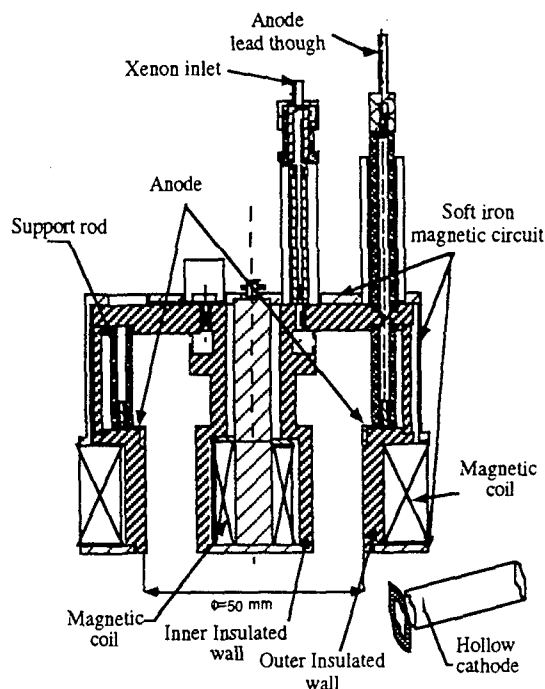


FIG 1 : Description of the SPT-50 thruster studied at Ecole Polytechnique.

The thrust was measured at RRC Kurchatov Institute, using a thrust scale, designed on the principle of a torsion scale with reaction. This scheme ensures a fixed position of the thruster in space during the measurement of thrust, which eliminates the effect of the rigidity of current and gas leads on the accuracy of the thrust measurement. The ion current was measured, at Ecole Polytechnique, on a metal target: 30 cm in diameter biased to -30 V located at a distance of 35 cm from the exit of the thruster.

III. ENERGETIC EFFICIENCY AND THRUST.

Figure 2 presents the variation with the gas flow of the thrust and the thrust efficiency. Note that at constant discharge voltage and magnetic field, the thrust dependence is linear for values $V_d = 300$ V and $B_r^{\max} = 170$ Gauss. The thrust efficiency increases

until the flow rate attains 1 mg/s and then saturates at 0.44.

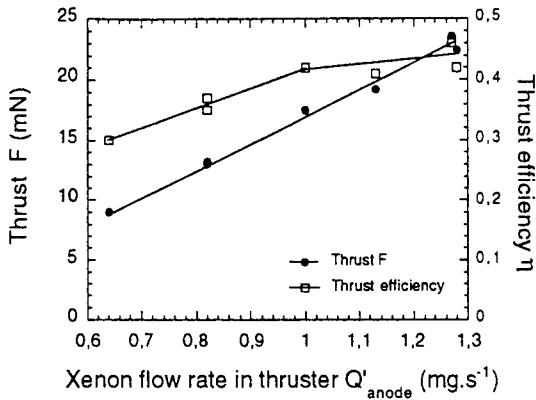


FIG 2 : Dependence on the gas flow of the thrust and thrust efficiency. The discharge voltage was 300 V and the optimal radial magnetic field value is 170 Gauss.

Figure 3 shows the variation with the discharge voltage of the thrust and the thrust efficiency. The mass flow rate was 1 mg/s and $B_r^{max} = 170$ Gauss. For comparison, we also plotted the thrust efficiency of SPT-20⁴.

The thrust increases with the discharge voltage and reaches 19 mN at a discharge voltage of 350 V. The thrust efficiency also increases with the discharge voltage from 0.18 to 0.44 when the discharge voltage varies from 110 to 350 V. It seems that the thrust efficiency saturates at a discharge voltage of 300 V. The thrust efficiency of SPT-50 is higher than the thrust efficiency of SPT-20 but their behavior on the discharge voltage is similar. Thus, the gas flow rate and the discharge voltage are important parameters in the discharge of SPT-50. Nevertheless, for SPT-50, the thrust efficiency is acceptable for spatial applications.

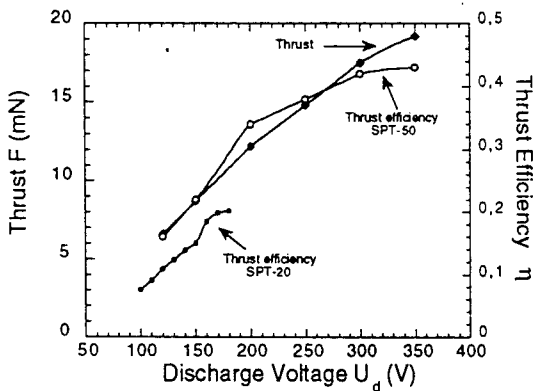


FIG 3 : Dependence on the discharge voltage of the thrust and thrust efficiency. The gas flow rate was 1 mg.s⁻¹ and the optimal radial magnetic field value is 170 Gauss.

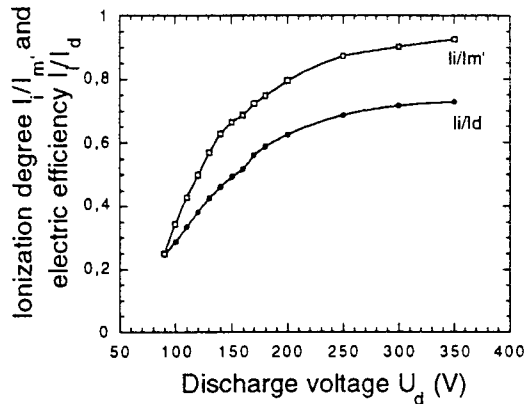


FIG 4 : Dependence on the discharge voltage of the degree of ionization and the energetic efficiency. The gas flow rate was 1 mg/s and the optimal radial magnetic field value is 170 Gauss.

Fig. 4 shows the variation of the ratios I_i / I_d and I_i / I_m with the discharge voltage. The ratio I_i / I_d characterizes the energetic efficiency of the thruster, while the ratio I_i / I_m is the degree of gas ionization (I_m is the current equivalent of the gas flow, assuming a total single ionization). When the discharge voltage is enhanced from 90 to 350 V the degree of ionization goes up from $I_i / I_m = 0.12$ to 0.85, while the ratio I_i / I_d varies in the range 0.28 to 0.73.

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PIC-MC Modelling of a RF Magnetron Discharge

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1. Introduction

Magnetron discharges are widely used as plasma devices for etching, sputtering or thin film deposition. Initially designed to work with DC power, the need for dielectric or semiconductor surface modification applications require high-frequency excitation.

In spite of their wide industrial utilisation, the understanding of the main phenomena occurring in magnetron discharges is far from being complete. The difficulty comes from the strong non-uniform electric and magnetic fields which act on the charged particles in front of the cathode.

The widely accepted contribution of ions to secondary electron emission in DC magnetron discharges is reduced in low-pressure RF (13.56 MHz) ones in which the volume production of charged particles by the RF heating of bulk electrons becomes non-negligible.

Previous dimensional models for the magnetron discharges have been developed. Some MC simulations [1,2] were accomplished for the DC case, and a kinetic model for an 1D ideal RF magnetron model was proposed by Lieberman [3].

The present model, based on a Particle-in-Cell Monte Carlo (PIC-MC) simulation, similar to Birdsall model [4], was carried out with the aim to simulate the plasma behaviour in the RF magnetron discharge and to get information on charged particle densities, electric field and ionisation source distributions during the RF period.

2. Model

2.1 Theoretical background

All computations were done for a circular planar magnetron and, due to the symmetry with respect to the central axis, the problem was reduced for the PIC to a rectangular domain (2D) bounded by this axis and by the vessel walls. The static magnetic field map, close to the target, was obtained by fitting the experimental data recorded on our device. The 2D electric field map was obtained by solving Poisson's equation at each time-step. Between two successive collisions, the plasma charged particles, represented in PIC models by macro-particles, move according to Lorenz force:

$$\ddot{\vec{x}} = \frac{q}{m} (\vec{E} + \dot{\vec{x}} \times \vec{B}) \quad (1)$$

where \vec{x} , $\dot{\vec{x}}$ denote the space and velocity co-ordinates (or a point in phase-space), q represents one elementary signed charge and m denotes the mass of concerned particle. Practically, ions are not sensitively affected by the presence of the magnetic field (typical \vec{B} values are of some hundred Gauss).

2.2 Numerical implementation

The boundary conditions necessary to solve the potential equation were imposed from the experimental electric circuit and device geometry. The anode is constituted by the chamber walls for which the potential is zero while the powered cathode is assumed as biased to RF voltage shifted down from zero by a DC negative voltage (V_{DC}). This bias is due to: i) the capacitive coupling between the RF supply and discharge electrodes throughout cathode dielectric, ii) to a very large ratio of the two electrode areas and iii) to the presence of magnetic field close to the target electrode. According to Lieberman [3] the peak-to-peak RF voltage (V_{pp}) can be approximated by the double of $|V_{DC}|$ bias. Above Dirichlet conditions are completed by a zero Neumann boundary condition on the central axis.

Actual model assumes a constant value for the potential all along the target radius. This means that the charge distribution on insulating target surface created by ion collection is perfectly neutralised by electrons for each moment and position on the surface.

Due to the cylindrical symmetry of the discharge device, the azimuthal component of electric and magnetic fields are zero. Thus, only the radial distance from the central axis and the axial distance from the target surface are stored for the calculation of macroscopic discharge parameters. The contribution of each macro-particle to the closer mesh nodes was weighted as indicated in [4].

High expected gradients of electric fields in front of the cathode compel us to work with a variable step on the two axis. With above boundary conditions and every step recalculated source term, the 2D potential map was numerically obtained by the over-relaxation

method. The axial and radial components of the electric field are easy to compute from potential map.

In these fields, the particle orbits are calculated integrating the motion equation (1) by using a quality control Runge-Kutta routine [5]. The time-step was taken so that the corresponding displacement of electrons was smaller than the mesh cell length. The concept of virtual collision frequency, detailed in [6], was used for higher computation speed.

2.3 Physical aspects.

Present simulation was performed with Xenon as buffer gas. Collision cross-sections for momentum transfer were taken from [7], for total excitation from [7] and for single ionisation from [8]. For the various involved collision process, differential cross sections were assumed as having almost the same angular dependence for a given incident electron energy. According to McDaniel [9], this approximation is reasonable in the case of noble gases. Energy dependence of electron deflection by Xenon atoms in elastic and inelastic collisions was taken from [10,11]. The anisotropy becomes non-negligible for energy higher than 5eV. Data are available up to 500eV.

The electric circuit is closed by the electrons which escape from magnetic field and reach the anode. At the beginning of simulation only secondary photoelectrons release the cathode due to the photoelectric effect of UV resonant radiation emitted by excited plasma atoms. Photoelectron emission is considered only if the photon falls on the cathode surface, and the corresponding solid angle leads to a probability of 0.3. Excitation processes were regarded as corresponding to an overall energy level for which an average lifetime of 10ns was assumed. The de-excitation of this state was randomly produced according to an exponential decay law and the self-absorption phenomenon was neglected. The relative importance of this process is weakened after some periods in favour of secondary electron emission due to ion bombardment of the cathode characterised by γ coefficient. For a BN cathode material considered here and ion energy below 1keV, the value of γ is about 0.1.

We completely neglect the Coulomb scattering of charged particles (electron-electron or electron-ion collisions) and also the production of doubly charged and excited ions. According to the small sheath thickness, even for long ion time of flight the resonant charge transfer from ions to neutrals could be neglected as a first order approximation, nevertheless it will be taken into account.

3. Expected results and discussions

The present model was developed for the study of the sputtering of boron nitride (BN) and the plasma

behaviour in a RF magnetron discharge. For this reason it is important to control the energy and the flux of ions which arrive on the BN target and control the sputtering yield and the secondary emission. The model provides also the temporal evolution and spatial distribution of excitation and ionisation events. This permits to compare the production of new electrons by bulk plasma heating or by secondary emission due to ion bombardment on the target.

Results of the model are planned to be compared to experimental ones, in particular for spatial distributions of the line intensities observed by optical emission spectroscopy for Xenon and also for sputtered materials. Experimental results indicate that the RF magnetron discharge regime changes for a critical pressure value of a few mTorr. It is also interesting to test the model against this experimental observation and eventually to explain it.

In order to explain the differences in the transport of charged particles into the DC and RF magnetrons the results of proposed model can be directly compared with previous DC MC model [1] or with 1D analytical one [3] for an ideal magnetron.

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Distribution of Surface Discharge for Ozone Generation

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1. Introduction

Surface discharge shows high performance for industrial uses such as ozonizers, flue gas treatments, UV sources and other non-equilibrium plasma processes[1]. Some workers have studied the fundamental mechanisms with respect to the influences of the surface charges on discharge channel extensions, the polarity effect of an applied voltage and the diffusion processes of generated ozone [2].

In this report, we present the distribution of discharge channels in surface discharge and the electrode design method in the case of narrow mutual pitch of surface electrodes for high concentration ozone generation.

2. Experimental setup

The electrode arrangement consists of the surface high voltage electrodes on a dielectric plate and the rear earth electrode as shown in Figure 1. We prepared two types of surface electrodes with wide and narrow mutual pitch for electrical and optical measurements. For a wide mutual pitch of 5mm, the metal wires with a 0.3 mm diameter were fixed on a 1.8 mm thick glass plate. For a narrow mutual pitch under 1 mm, metal stripes were printed on a ceramic plate or glass coated metal plate. The distribution of discharge channels in surface discharge was observed by using high speed CCD camera system (Princeton Instruments, ST130).

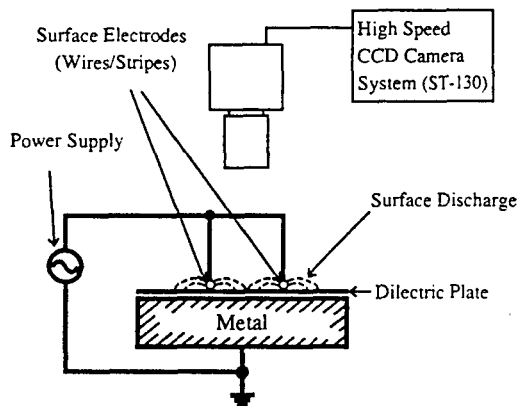


Fig.1 Electrode configuration for optical and electrical measurements

3. Results and discussions

3.1 Wide pitch surface electrodes

In the case of mutual surface electrode pitch of 5mm, the distributions of discharge channels were observed as shown in Figure 2. Gas is dry air whose pressure is 1.7

bar and the dew point is below -60 degree.

Figure 2 shows the light emission from surface discharge observed at the exposure time of $100 \mu s$ for both polarities of an applied voltage (6kV). At the negative polarity, the strong light emission occurred in the neighborhood of the wire electrodes, and at the opposite positive polarity, it occurred in an extensive region. The half width at half maximum of light intensity is 1.3 mm at a positive polarity and 0.7 mm at a negative polarity; the former is about twice the length of the latter.

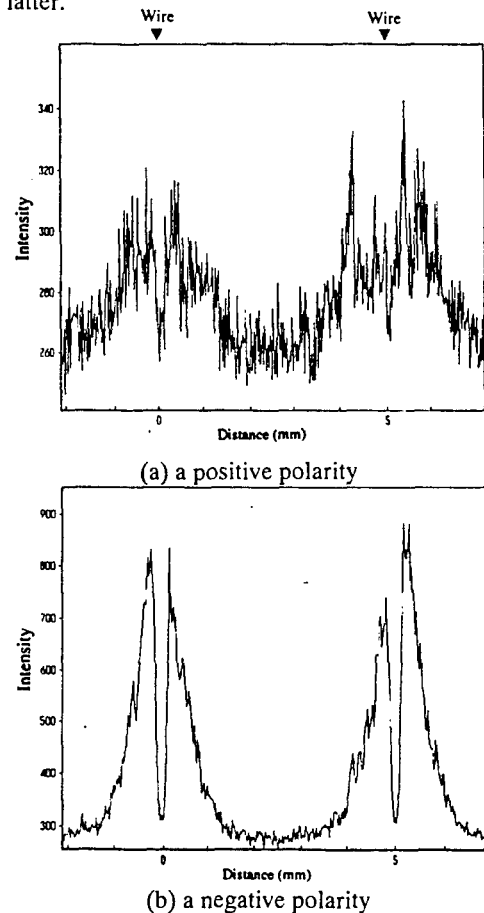


Fig. 2 Collective distributions of discharge channels for both polarities in the case of mutual pitch of surface electrodes of 5 mm (exposure time; $100 \mu s$)

To observe the individual discharge channel at a positive polarity, the exposure time is reduced to 20 ns and 6 ns as shown in Figure 3. The discharge channel length at the exposure time of 6 ns is shorter than that at 20 ns. In some cases, it can be seen that the luminous parts of discharge channel are apart from wire electrodes, as shown in Figure 3 (b). We think the active region of surface discharge is the discharge channel head.

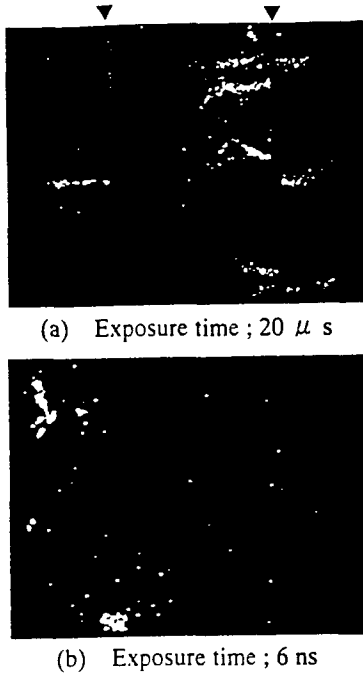


Fig. 3 Distribution of individual discharge channels at a positive polarity in the case of mutual pitch of surface electrodes of 5 mm.

3.2 Narrow pitch surface electrodes

For a narrow mutual pitch of 0.25 mm, the distribution of discharge channels was observed as shown in Figure 4, where dielectric material and surface electrode is made of AlN and wolfram, respectively. The thickness of AlN is 0.25 mm. The bright part of surface discharge is the center of mutual pitch of surface electrodes. This result is the same as reference [1] and is caused by discharge channel being no longer perpendicular to surface electrode.

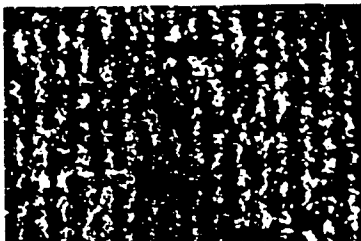


Fig. 4 Collective distribution of discharge channels in the case of mutual pitch of surface electrodes of 0.25 mm

The narrow pitch of stripe electrodes decreases the electric field along the dielectric surface and increases breakdown voltage. The electric field analysis by using the high speed surface charge simulation method (HSSSM) was carried out. Figure 5 shows the results of calculated electric field on dielectric surface, when the applied voltage is 3 kV. The increment of dielectric thickness causes the decrement of electric field regardless of dielectric constant. It is considered

that the electric field near surface electrodes is so high that the breakdown occurs from the Paschen minimum distance of about 5 μ m.

The measured breakdown voltage was compared with the calculated electric field at 5 μ m from surface electrode. The experimental setup consisted of stripe surface electrode and glass coated metal plate electrode, whose dielectric thickness is 0.2 mm. Table 1 shows the measured breakdown voltage and the calculated electric field in the case of a constant applied voltage of 4 kV. At the pitch of 0.5 mm, the calculated electric field decreases with the pitch, and so the breakdown voltage increment was verified. As a result, we found that the aspect ratio of the strip electrode pitch to the dielectric thickness should be more than 1 regardless of dielectric constant.

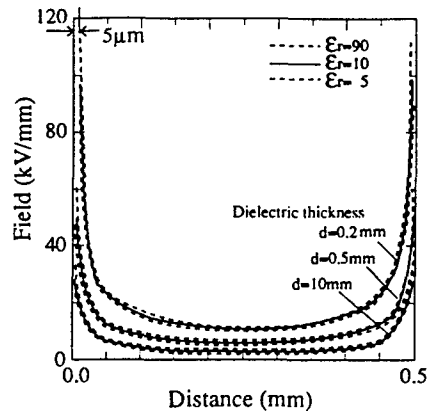


Fig. 5 The calculated electric field on dielectric surface

Table 1 The measured breakdown voltage and the calculated electric field in the case of 4 kV

Surface Electrode Pitch, mm	0.2	0.5	1.0
Breakdown Voltage, kV	3.2	2.1	2.0
Electric Field, kV/mm	67	82	88

4. Conclusions

At a negative polarity, the light intensity from surface discharge increases steeply in the neighborhood of the surface electrodes, and at a positive polarity its distribution is twice as extensive. The extension speed of discharge channel is observed in the time range of some ns for a positive polarity. The narrow pitch of surface electrodes decreases the electric field along the dielectric surface and increases breakdown voltage. It was found that the aspect ratio of the strip electrode pitch to the dielectric thickness should be more than 1.

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Comparative behaviour of DC positive point-to-plane discharges in Nitrogen and dry Air for pressures around 50 Torr

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1. Introduction

A lot of work has been performed concerning corona discharge in ambient air, but only a few studies are dealing with the intermediate (50 - 400 Torr) pressure range for DC discharges with inhomogeneous field [1,2], and no systematic drawing of V-I characteristics and recording of related current impulses were published.

The aim of the present work is to contribute to a better knowledge of the discharge in the lower part of this pressure range, comparing pure Nitrogen, with Dry Air (cylindered) which presents electronegative properties. It is a development of studies initiated for lower pressures in the frame of a franco-hellenic collaboration [3,4] and recently pursued [5-7].

2. Experimental procedure

A rhodium point electrode with 100 μm tip curvature radius is positively stressed with a 0-30 kV DC power supply, whereas the grounded electrode is a stainless steel plane. In order to access to the steepest parts of the characteristics, a 200 M Ω load resistor is used in the external circuit. Current impulses as well as the DC component are visualized on a digital oscilloscope and recorded by a printer or a plotter.

Measurements are performed with pressure p in the 50-70 Torr range and gap length d in the 1.0-1.4 cm range, in such a way that the same values of $p \cdot d$ can be obtained with different values of p and d .

3. Comparison between N₂ and Dry Air for $p = 50$ Torr and $d = 1$ cm

In this pressure range, for the given load resistor and within the limits of the power supply, three distinct regimes successively occur in Nitrogen with increasing applied voltage [6,7]; they can be followed either visually or along the V-I characteristic curve (figure 1). As the applied voltage is increased, the discharge inception occurs with a thin luminous anodic layer on the point surface, becoming brighter as the gap voltage V increases. This region, hereafter designed as "Luminous Point" (LP), presents similarities with the dark self-sustained discharge [5]. For increasing values of the applied voltage, V drops suddenly (for average current about 10 μA) and remains quasi-constant. The

visual aspect is globally cylindrical with decreasing light intensity from the point to the plane and presents a bright cathodic sheath. This regime is called "Glow-Like" (GL). When the applied voltage is further increased, a sudden growth of V is observed, followed by a second decrease as the current rapidly increases (and would lead to arc if allowed by the external impedance). To avoid hazardous interpretations, this regime is simply called "Total Discharge" (TD).

For Dry air, the LP regime is identical, except that the anodic layer is more diffuse and tends to spread up along the conical part of the rod. But the V-I characteristic (figure 1) appears different after the first voltage drop. The discharge seems to stay in the GL regime for much higher values of the applied voltage. An increase of V is observed, but less important than in the case of Nitrogen. The transition to TD, if any, occurs at much higher current values.

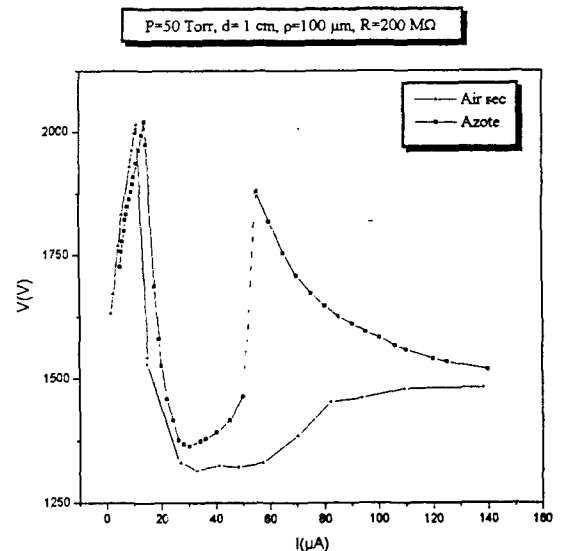


Fig. 1. V-I characteristics at $p = 50$ Torr for Nitrogen (•) and Dry Air (+).

In Nitrogen, space charge in the vicinity of the point consists in positive ions, the accumulation of which may be equivalent to a virtual anode with a more important curvature radius as the real one. In Air, the presence of negative ions in the gap modifies the local space charge field. The LP regime is controlled by the applied voltage, and GL by the current flow, so that the difference between the curves concerning Nitrogen and

Dry Air, which mainly occurs in this last regime, is probably due to the different nature of space charge. Each of the three above mentioned regimes is characterized by typical shapes of current impulses superimposed to the DC component of the discharge current [6,7] which may be recognized for both gases.

4. Variation of gap length and pressure

The gap length has been varied for Nitrogen and Dry Air, keeping constant the pressure (figures 2 and 3). A translation of the gap voltage to higher values is observed when d is increased. But in the case of Nitrogen, the extension in current of the GL regime correlatively decreases.

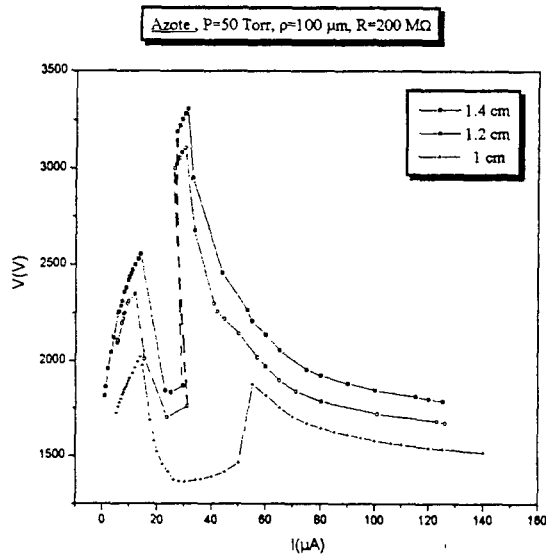


Fig. 2. V-I characteristics at $p = 50$ Torr for Nitrogen with varying gap length.

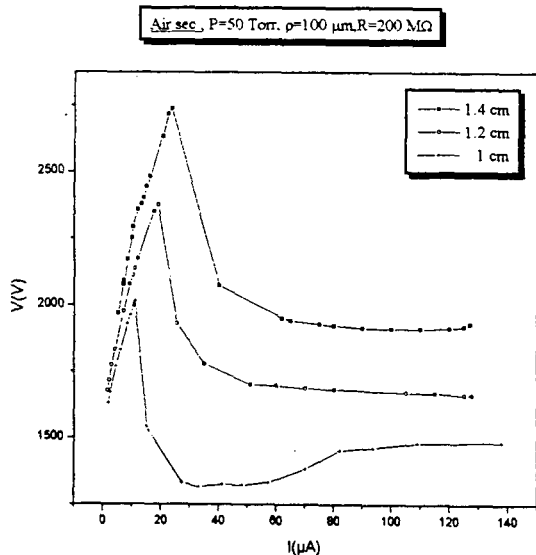


Fig. 3. V-I characteristics at $p = 50$ Torr for Dry Air with varying gap length.

Measurements performed for $p = 60$ and 70 Torr and compared with the above results show that the evolution of phenomena with the product $p.d$ is different when either p or d is varied, the other one being kept constant. As a consequence, $p.d$ does not appear to be a similarity parameter.

5. Concluding remarks

Even if the visual aspect of the discharge is similar for both gases, the observation of the V-I characteristic curves and of the related current impulses show that the behaviour of discharges in Nitrogen and Dry Air are quite different, especially when the influence of space charge is predominant, i.e. in the GL regime, this latter covering a more extended current range in Air.

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Effect of sample-cathode shape in DC glow discharge ion source for mass spectrometric analysis.

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Glow discharge sources have been widely used in analytical chemistry, essentially as sources for optical emission or atomic absorption spectrometry and more recently for mass spectrometry. The successful application of glow discharge in mass spectrometry has shown up excellent capabilities for the characterization of solids [1]. Because the elemental (and isotopic) composition of a material defines its chemical and physical properties and *in fine* its quality, more sensitivity and reliability in analytical measurements are needed to qualify recent materials. To improve the figures of merit in GDMS, a better understanding of the physical processes that occur in the ion source is required. In this paper, we describe the effect of the cathode (sample) geometry on the argon plasma and the consequences on analytical capabilities.

1. Instrumentation

All measurements were done using the VG9000 high resolution glow discharge mass spectrometer (FISONS Elemental, UK) with the so-called MegaCell source for pin samples. In direct current GDMS the sample functions as the cathode and the plasma cell as the anode of the discharge chamber. Typical conducting samples are cylindrical shaped : 15-20 mm length, 1-3 mm diameter and penetrate 5-10 mm into the plasma. A low pressure (0.5-1.5 torr) of high purity argon is introduced. The potential difference around 1kV leads to a discharge current of some mA. The cathode material is sputtered by argon ions and fast neutrals and the atoms ionized in the plasma enter the mass spectrometer to be measured. These conditions usually give good analytical results but some of the operating parameters must be kept constant to ensure low deviation in measurements. More often the ion source parameters are fixed according to empirical or practical considerations. Thus, the discharge cell was modeled to study the influence of the different parameters.

2. Simulation of the glow discharge

A self-consistent, two-dimensional hybrid fluid-particle model is used to study the plasma produced in the MegaCell ion source of the spectrometer [2-3]. Calculations of the properties of steady-state glow discharge in pure argon are performed for two different shapes of the cathode.

In a pin-sample configuration (length 9mm ; diameter 3mm, referred as A) we first studied the formation of the plasma region by increasing the pressure from 0 to 1 torr, the voltage being fixed at 1kV. From 0.5 torr, a plasma forms in a ring around the cathode as shown by the ion density profiles in figure 1-a.

The existence of an electric field inversion in the plasma can be seen from the calculated equipotential contours. With such a field reversal, ions which can reach the anode are those created in ionization events on the anode side of the potential maximum. None of the ions created on the cathode side of this maximum can be drawn into the mass spectrometer.

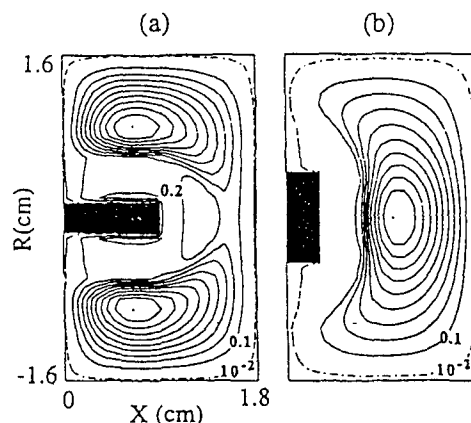


FIG. 1. Contours of constant ion density calculated in 0.5 torr Ar for (a) A and (b) B shaped cathodes (see text).

The calculated argon ion current density is maximum along the side walls and not in the extraction plane. See figure 2-a for current density in the extraction plane.

By changing the cathode geometry (length 3mm ; diameter 9mm, B shape) we point out that the plasma region is in front of the cathode. A maximum in the ion density distribution is observed on the axis of the cell (figure 1-b) with an increase of a factor 4 compared with the baseline geometry (A). Again, a field reversal exists but is now centered on-axis, generating an increase in the Ar^+ density on the extraction plane by a factor of 10 (figure 2-b).

These results suggest that the analytical performance and especially sensitivity of glow discharge mass spectrometric analysis can be enhanced by suitably choosing the sample geometry.

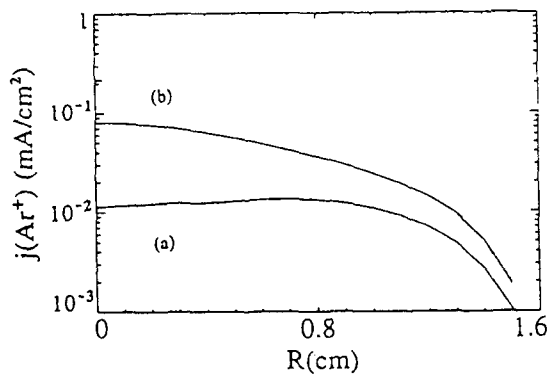


FIG. 2. Ion current density distribution along the extraction plane as a function of the distance from axis for (a) A and (b) B cathode shapes and 0.5 torr argon pressure.

3. Experimental results

In order to define the experimental operating conditions of the ion plasma-source, the voltage-current characteristics for a high purity copper cathodes have been measured. The data for 0.5, 0.9 and 1.4 torr argon pressure are reported in figure 3 for the two cathode shapes discussed above. As expected, the discharge current increases with the pressure and the voltage. Though there is a small difference in the surface areas of the cathodes (respectively 0.9 and 1.5 cm² for A and B shaped cathodes), the electrical current for the large diameter cathode is higher.

In these experiences, the cell was cryocooled with liquid nitrogen and the discharge voltage was regulated. The pressure was measured using an additional system that we have to develop because no reliable measurement can be done with the spectrometer in its standard configuration. Standard deviation in measurements did not exceed 0.1 torr.

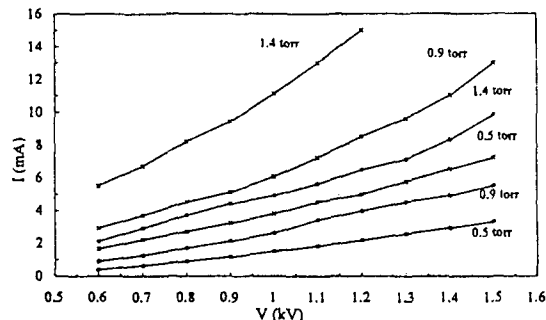


FIG. 3. Experimental voltage-current characteristics for 0.5 ; 0.9 and 1.4 torr argon pressure. Circles are for the A geometry and crosses for B.

The ion beam intensities collected in the mass spectrometer of each isotope of argon, copper and some trace impurities are measured for each running point of the V-I characteristics presented just before. Integrated peak areas for ⁶³Cu⁺ and ⁴⁰Ar⁺ ions (major abundance isotopes) are reported in figure 4 for A and B cases. As predicted by the calculations, the ion signals increase by changing the sample geometry from pin to quasi-disk shape.

A one order increase in the ion intensities is confirmed by the experience.

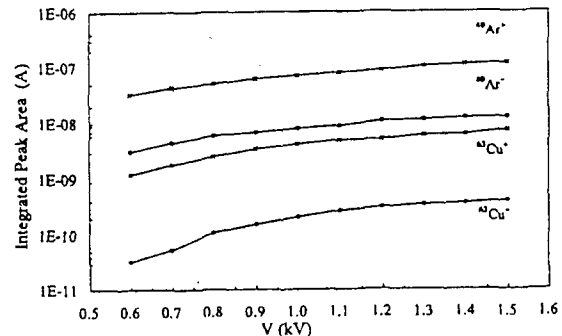


FIG. 4. Integrated peak areas for argon and copper ions as a function of the voltage measured for 0.5 torr. Circles are for the A geometry and crosses for B.

4. Summary

Calculations of the properties of the ion plasma-source of the VG9000 spectrometer have been performed for pin and disk cathode geometries in pure argon discharge. Results are consistent with calculations for such ion sources using a one-dimensional model [4]. Experimental data validate the model and its predictions regarding the ion fluxes arriving in the extraction plane. From this, we have simulated an increase of a factor 10 in the sensitivity of the analytical technique considering principally the field reversal in the negative glow of the discharge. Thus, analytical performances can be improved by a suitable adjustment of the cathode shape.

Moreover, the distance from the cathode top to the exit slit, a typically empirical parameter usually carefully adjusted by users have been shown to have a little influence. This result was obtained by reducing the anode length [3].

Further, the controlling quantities for the sputtering rate of the cathode due to Ar⁺ bombardment, that means the argon ion fluxes to the cathode and the energy of these ions, can be obtained by the model. First results indicate that the predicted erosion profile shapes are in good agreement with experiment. However, as pointed out in reference [5] sputtering by fast neutrals is also important.

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CHARACTERISTICS OF LOW POWER HF 10-CM TECHNOLOGICAL ION SOURCE

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In [1] the low power HF ion source was represented, which operational principle was based on the excitation of electrostatic waves. A.F. Alexandrov et al. [2] showed that contrary to helicons, electrostatic waves excitation in plasma, located in the external magnetic field, is independent on plasma density and can occur at low HF power input. Under conditions of electrostatic waves excitation, HF fields penetrate into plasma volume and electrons are effectively heated due to Landau damping mechanism [2]. The presence of external magnetic field in addition helps to confine electrons in the discharge and decrease the power losses for the discharge sustaining. The construction of the HF ion source is described in details in [1]. The present paper represents the test results of the HF ion source models with magnetic systems based on one, two and three magnetic rings. The increase of the number of magnetic rings was followed by the increase of the magnetic field at the source axis from 180 to 350 Gs. Models of HF ion source with convex and concave grids of ion optic system (IOS) were tested.

1. Results of Technological HF Ion source experimental tests.

Fig.1 shows the extracted ion currents of different gases, obtained at fixed HF power input to the ion sources with different magnetic systems. One can see that introduction of magnetic field leads to significant (about 3 times) increase of the ion current but the multiplication of the magnetic rings number results only in 20-30% increase of the ion current. That means that in construction of technological ion source it is reasonable to utilize magnetic system, based on one or two magnetic rings.

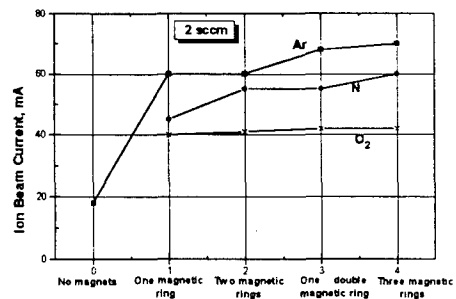


Fig.1. The extracted ion currents of different gases, obtained at fixed HF power input to the ion sources with different magnetic systems.

Ion beam profile at a given distance from the ion source is controlled by three parameters:

- 1) ion beam profile at the exit of IOS;
- 2) divergence of the elementary ion beam, extracted from the single hole of IOS;
- 3) shape of the grids of the IOS.

At small distances from the IOS the first and the third factor play essential role, while at the large distances from IOS two last factors are much more important because in this case every hole of IOS contributes nearly to any point within the ion current profile. Fig.2 shows the ion beam profiles, measured close to the exit of IOS. One can see

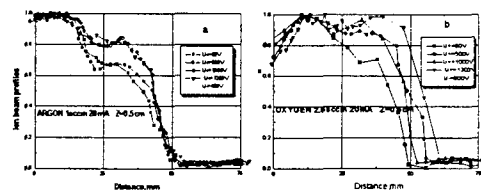


Fig.2. Ion beam profiles, measured close to the exit of IOS.

that the homogeneity of the ion beam is high, especially at large accelerating potentials. One can also observe not-pronounced but

nevertheless existing structure of the ion beam profile. Most probably it can be related to the spatial distribution of electrical field in the excited electrostatic wave. This idea is confirmed by the measurements of current distribution near the IOS at zero acceleration and deceleration potentials, i.e. in the case when electrons and ions can go out of the ion source only due to their velocities, obtained in plasma volume and near emission electrode sheath. One can see from Fig.3 that in this case electrons are emitted from the ring, situated close to the center of gas discharge chamber. The position of electron ring correlates with the structure of the ion current, observed in case of applied voltage to the electrodes of IOS.

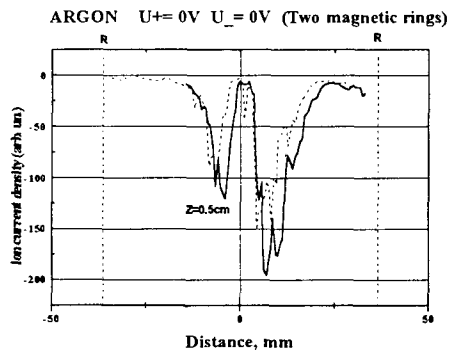


Fig.3. Current distribution near the IOS at zero acceleration and deceleration potentials. Solid and dashed lines represent currents measured at zero and -12V potentials of the Faraday cup.

Fig.4 represents the ion beam profiles, measured at the distances 5 and 22 cm from the HF ion source with concave IOS and different magnetic systems. One can see that ion beam profiles, obtained with different magnetic systems at the distance 22cm, are close to each other in spite of the fact that ion beam profiles, measured at the distance 5cm have remarkably different shape. This is the result of the influence of the divergence of the elementary ion beams, produced by every hole of the IOS.

Ion beam current density measurements, carried out at different distances from IOS showed that the divergence of the ion beam, extracted from the HF ion source with installed magnetic system and used shape of concave type IOS is about 13-15°.

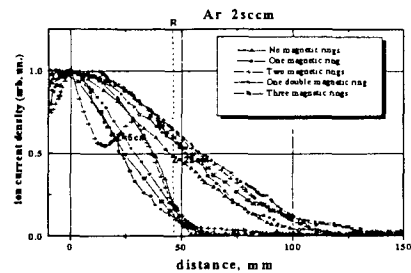


Fig.4. Ion beam profiles obtained with different magnetic systems and concave type IOS.

Results of ion beam current density measurements at the distance 40cm from IOS for different working gases: Ar, O₂, N₂ and air showed that the working gas change does not influence the shape of ion current density spatial distribution. In order to find the conditions, when the most uniform ion current density distribution can be obtained with concave grids, the dependence of Ar ion beam density on acceleration potential in the range from -300 V to -900 V at a constant ion beam energy was studied. Experiments showed that the best uniformity of the beam profile was at the potential of acceleration electrode about -500 V. The diameter of spot with 90 % uniformity reaches about 16 cm. The change of the uniform spot dimensions with the change of ion beam energy is negligible. But significantly higher uniformity of the ion beam can be achieved with convex grids, this fact can be brilliantly illustrated by Fig.5.

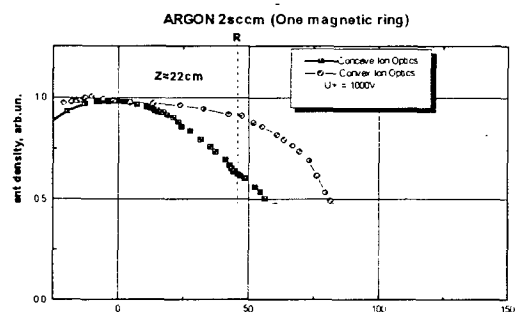


Fig.5. Ion beam profiles obtained with concave and convex grids.

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Mass spectrometric study of SF₆ plasma beam extracted from an ECR ion source

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1. Introduction

A SF₆ reactive ion beam etching (RIBE) system has been developed using an ECR ion source with a 3 grids beam extraction system. A better understanding and control of this etching process requires a knowledge of the composition of the ion beam and the neutral species extracted from the plasma through the grids. Therefore, a mass spectrometric study of the SF₆ plasma beam (ions + neutral species) has been carried out. The effects of the microwave power and the SF₆ gas pressure have been studied. Application to the RIBE of silicon is discussed.

2. Experimental arrangement

The experimental system is shown in figure 1. The sample to be etched is clamped on a moveable holder. In RIBE configuration, the surface of the sample is normal to the beam and located at near 25 mm away from the outer grid of the ion source. In mass spectrometric analysis, the substrate holder is removed and the plasma beam can reach the aperture of the spectrometer located at 100 mm opposite to the outer grid. The description of the ECR ion source is given elsewhere [1]. The diameter of the beam is 10 mm at the output of the source. Extracted current density of the beam is a few mA.cm⁻². The energy of the beam can be controlled between 60 eV and 2000 eV.

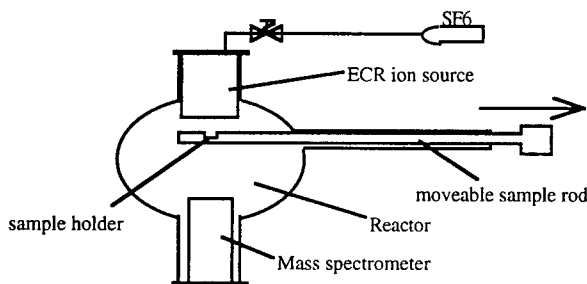


Figure 1 - Schematic drawing of the experimental setup

Reactor chamber is pumped down $4 \cdot 10^{-7}$ mbar. This pressure is measured with a Bayard-Alpert ionization gauge calibrated for nitrogen. When the SF₆ plasma is generated, the pressure is between $3 \cdot 10^{-5}$ and $5 \cdot 10^{-4}$ mbar according to the SF₆ gas flow injected in the source. This pressure is lower than the pressure in the plasma source because of the low conductance of the grids. The spectrometer, differentially pumped down 10^{-7} mbar, consists of an electrostatic energy analyzer (0 to 500 eV) coupled with a quadrupole mass filter (0 to 500 uma).

3. Results

3.1 Analysis of the ion beam

To limit the ion current coming into the spectrometer, the diameter of the aperture is reduced to 100 μ m. A correct fit of the parameters of the spectrometer allows to get a transmission factor independent of the ion mass. So the proportion of the different ions species is proportional to the intensity of each peak. Results are given in figure 2 and figure 3.

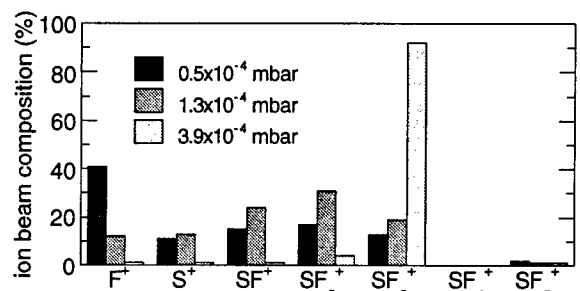


Figure 2 - Ion beam composition at 150 W microwave power for 3 SF₆ gas pressures.

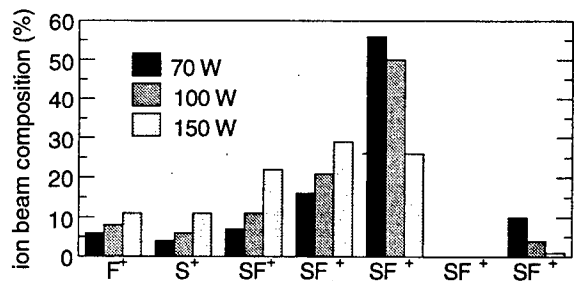


Figure 3 - Ion beam composition at $1.3 \cdot 10^{-4}$ mbar for 3 microwave powers.

At low pressure, F⁺ is the dominant ion (40%) whereas at higher pressure the fragmentation is less important and the proportion of SF₃⁺ is the highest. The increase in the microwave power allows to get a higher proportion of low mass ions. These results are qualitatively consistent with those given by ref. [2]. The FWHM is lower than 10 eV for each peak.

3.2 Analysis of the neutral species

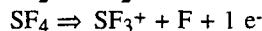
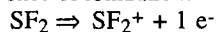
To avoid the penetration of the ions into the spectrometer, its aperture is biased positively and the conditions of beam extraction are chosen in the way to increase the broadening of the ion beam. The diameter of the aperture is 1 mm to achieve a high enough concentration of neutral species in the ionization chamber of the spectrometer. These neutral particles are partially ionized by electron impact. The energy of the

electrons can be adjusted between 10 eV and 70 eV. At 70 eV, the SF_5^+ , SF_4^+ , SF_3^+ , SF_2^+ , SF^+ , S^+ and F^+ ions are detected. The appearance potentials of the main ionic species created in the spectrometer have been measured (table 1) when no plasma is generated (plasma off) and when a plasma is generated in the ECR ion source (plasma on).

	SF_5^+	SF_4^+	SF_3^+	SF_2^+
plasma off	16	20	20.5	28
plasma on	15.5	20	13	11

Table 1 - Appearance potential in eV of SF_x^+ ($2 \leq x \leq 5$) under plasma on and off

In plasma off condition, the experimental values are in agreement with the measurements given by ref. [3] for the appearance potential of ions produced by electron impact dissociative ionization of SF_6 . For SF_3^+ and SF_2^+ , differences appear between plasma on and plasma off. They are attributed to the existence of SF_2 and SF_4 radicals when the plasma is on according the following sequence of ionization:



Ionization energy of the first reaction is measured at 11 eV and is in agreement with the value of 10.1 eV calculated by ref. [4]. Dissociative ionization energy of the second reaction is measured at 13 eV. Theoretical estimation of this value can be obtained by summing the calculated values [4] of the SF_3 -F bond energy (4.2 eV) and SF_3^+ ionization energy (8.4 eV) which gives 12.6 eV. This value is close to our experimental value in plasma on. The rate of dissociation of SF_6 in the ion source is calculated by:

$$R = \frac{H_{127}^{off} - H_{127}^{on}}{H_{127}^{off}}$$

With, H_{127}^{on} (H_{127}^{off}) height of the SF_5^+ peak in plasma on (plasma off) which is attributed to only SF_6 gas and is proportional to SF_6 pressure. High value of R (80%) is observed at low pressure and high microwave power (fig. 4) because the mean free path of electrons in the source is higher and thus the ECR effect is more efficient.

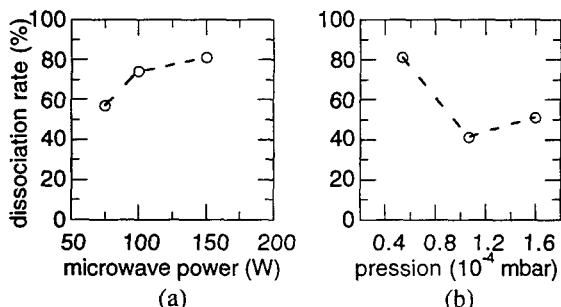


Figure 4 - Dissociation rate of SF_6 :

- (a) for 3 microwave powers at $1.3 \cdot 10^{-4}$ mbar
 (b) for 3 pressures at 150 W

This condition of operation corresponds to high value of the extracted beam current with a large proportion of F^+ ions in the beam (fig. 2 and 3).

Concentration of SF_4 and SF_2 radicals has been estimated using:

- the mass spectrum of fragmentation of SF_6 obtained in plasma off condition,

- the mass spectrum of fragmentation of SF_4 given by ref. [5],

- the ratio of the cross section of dissociative ionization of SF_4 ($\Rightarrow SF_3^+$) over the cross section of dissociative ionization of SF_6 ($\Rightarrow SF_5^+$) estimated at 3.

The concentration of atomic fluorine is deduced from the difference between the total concentration of fluorine injected in the source (determined in plasma off) and the concentration of fluorine coming from SF_6 in plasma on and coming from SF_4 and SF_2 radicals.

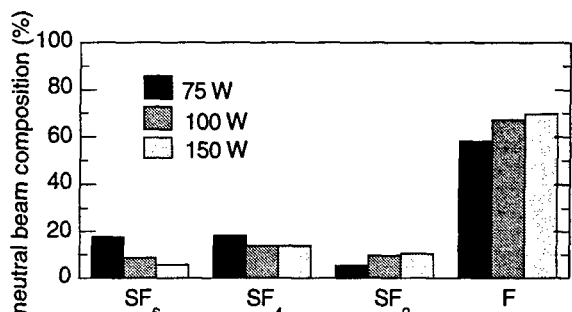


Figure 5 - composition of the neutral species

High proportion of fluorine is observed at $5.3 \cdot 10^{-5}$ mbar and 150 W (fig. 5). This behavior is correlated with high rate of dissociation and high proportion of F^+ in the beam. These conditions of operation have been chosen to study the RIBE of silicon [6]. The neutral flux of fluorine is roughly estimated at $2 \cdot 10^{17} \text{ cm}^{-2} \text{ s}^{-1}$ using the measurement of the SF_6 flow injected in the ion source and the knowledge of the dissociation of SF_6 in the plasma (in our RIBE conditions, each SF_6 molecules gives 2.3 F atoms on average). Since the current density of the beam is about $5 \text{ mA} \cdot \text{cm}^{-2}$ [6], the ratio of the neutral flux of fluorine over the ion flux is evaluated at about 10. This result indicates the importance of the active neutral flux of fluorine in RIBE using SF_6 gas.

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Topic 19b

Special topic at the XXIII ICPIG :
High pressure, non-thermal plasmas.

Détermination of electron density and temperature of an E.C.R. plasma by V.U.V. spectroscopy

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Introduction

In Electron Cyclotron Resonance Ion Source, electrons are magnetically confined in a minimum-B structure. By interaction with a high frequency wave, they acquire energy enough to overcome the ionization potentials of neutral atoms and ions of the element injected in the source [1]. For a better understanding of E.C.R. plasma, it is important to determine the parameters that are responsible for the production of multicharged ions such as electron density and temperature. It is an acknowledged fact that E.C.R. plasmas always have cold electronic population. A V.U.V. spectrometer has been used to diagnose this population. After a presentation of the experimental set-up, we give some results in which electron density and temperature are determined according to a collisional radiative model [2].

Experimental set-up

A 3 m grazing incidence spectrometer is connected perpendicularly to the plasma chamber of the Quadrumafios source [3], where most of the multicharged ions confined in the resonance zone could be observed, as shown in Fig 1.

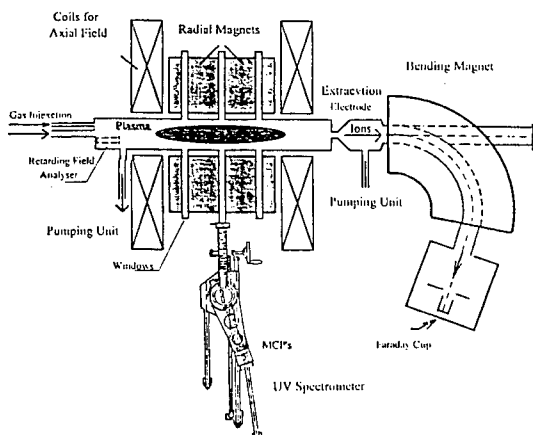


Fig 1. Quadrumafios source and V.U.V. spectrometer.

The spectrometer is equipped with a 600 grooves/mm grating blazed at 25.6 nm. The photons are detected by MCP's coated with MgF_2 .

The relative calibration curve has been determined by the branching ratio method which is directly applied to the plasma of the source. The part of the curve below 30 nm has not been yet obtained because of very weak line intensities emitted by highly charged ions in this source. This to be realized soon with a more powerful multicharged ion source. The relative intensity calibration curve has the profile indicated in Fig 2.

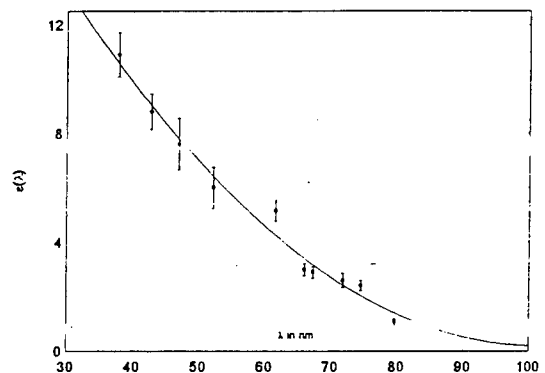


Fig 2. Relative intensity calibration curve for the 600 grooves/mm and MCP's.

Results and Discussion

The intensity line ratios method applied to the O V ion, gives us an estimation of electron density and temperature according to the coronal hypothesis. The V.U.V. spectroscopy only analyses a low energy electron population that is responsible for the first excited levels of O V. Indeed, the photon energies detected by our system are from 15 to 120 eV.

We firstly present the line intensity ratios which have a dependance on electron temperature and density as a function of the injected R.F. power and the gas pressure inside the plasma chamber.

As shown in Fig 3, the intensity ratios depending on temperature increase with R.F. power, whereas, those depending on density are decreasing. These curves are not corrected by the efficiency calibration

but they give the evolution of electron temperature and density. The evolution of the O^{4+} extracted current intensity from the Quadrumafios source is also plotted on the graph.

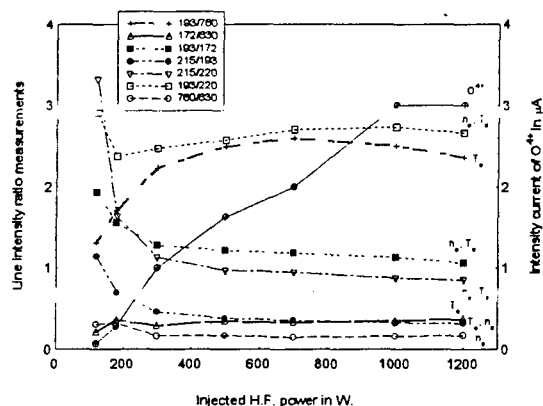


Fig 3. Line intensity ratio of O V in function injected H.F. power

The line intensity ratios that are only depending on T_e are 17.2/63.0 and 19.3/76.0 nm. These two ratios are a linear growing function of temperature. They increase by a factor 2 between 120 and 400 Watts then remain constant, while the O^{4+} beam current intensity is growing by a factor of about 50 from the ignition to 1200 W. When R.F. power is increasing the electron temperature should also grow up. This is observed at low power. The electron density is decreasing at low injected R.F. power and then remains constant. This electron density behavior was also observed on previous measurements made in our lab on Caprice source [4]. The 76.0/63.0 ratio is used to estimate the electron density because of the available part of the calibration curve. It varies from $5 \cdot 10^{11}$ to about $1.2 \cdot 10^{11} \text{ cm}^{-3}$ in the studied energy range.

Fig 4. shows the evolution of the same line intensity ratios, electron temperature and density dependant, as a function of O_2 gas pressure into the plasma chamber.

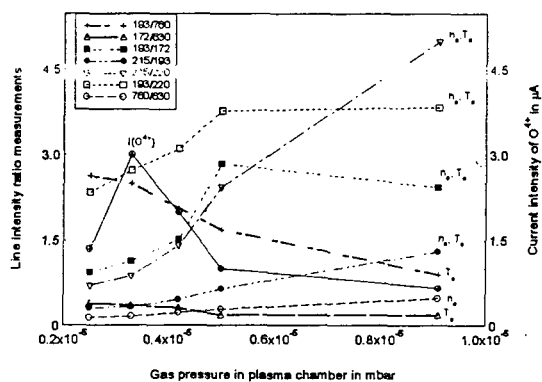


Fig 4. Line intensity ratio of O V versus gas pressure inside the plasma chamber

We note that the line intensity ratios which depend on electron density increase with the pressure and those which depend on electron temperature decrease with neutral pressure inside the plasma chamber. Among the line intensity ratios, some depend both on density and temperature. So we have taken into account the strongest dependency on these two parameters. The classical point of view generally adopted to explain the behavior of these curves, is that when gas pressure increases, collisions between electrons and other plasma particles also increase. Thus electrons loose their energy by collision processes. The electron temperature varies with gas pressure from 50 to 15 eV. The increasing electron density with the pressure can be explained by the higher production of low charged ions. We thus can imagine that cold electrons pulled out from neutral and monocharged ions are contributing to the electrons density which varies from $3.5 \cdot 10^{10}$ to $4 \cdot 10^{11} \text{ cm}^{-3}$.

Microwave interferometer was also installed on the Quadrumafios source providing a total electron density which is increasing with R.F. power from $2 \cdot 10^{11}$ to $4.5 \cdot 10^{11} \text{ cm}^{-3}$. This observed discrepancy relative to our results may come from the Maxwellian Electron Distribution Function used in the model. Therefore the excitation and ionisation rate coefficients calculated by theoretical method are no more valid. A recent paper by Sasaki et al. [5] shows effects of a hot electron tail on the line intensity ratios. applied to a heated R.F. helium plasma.

Conclusion

V.U.V. spectroscopy is a non invasive powerful tool used in the investigation of E.C.R. plasma parameters. In the future work, we will be able to give the ionic densities for an oxygen plasma as a function of R.F. power and gas pressure. Consequently these results should provide an estimation of the ion confinement times and thus more insights about transport phenomena which occur in the plasma of E.C.R. Ion Source.

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Effect of partial discharges on sulfur hexafluoride (SF₆) by-products

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1. Introduction

SF₆ is the most commonly used gas for electrical insulation. In order to have the alternative for gaseous electrical insulation, we have compared sulfur hexafluoride (SF₆) with the following gases : nitrogen (N₂) and the mixture SF₆/N₂ with 10 % SF₆; traces of oxygen (O₂) were systematically added to these gases. Partial discharges (P.D) have been produced in the test gases in order to determine precisely by analytical methods the nature of SF₆ and N₂ by-products and their quantity, and to deduce the real effects of toxic products. Experiments on SF₆/N₂ mixtures by-products have already been carried out by M.C. Siddagangappa and R.J. Van Brunt [1] : the absolute production of SO₂, SOF₄, SOF₂, SO₂F₂ and NO, N₂O was determined versus percent-by-volume concentrations of nitrogen between 0 and 100 %. In our study were introduced new parameters : temperature, pressure, partial discharges production time, traces of oxygen.

2. Production of partial discharges

A cell for the production of partial discharges with point-plane electrodes has been worked out by LGET : the combined effects of temperature, pressure and high A.C voltage have been taken into account (Figure 1).

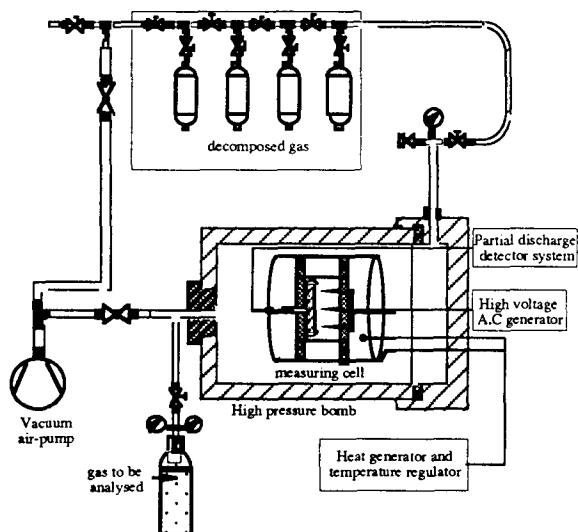


Figure 1. Apparatus for the production of partial discharges under pressure.

All the experiments have been done with point-plane electrodes and 2 mm air gap. Before filling up the cell with gas, a primary vacuum was obtained. A high A.C

voltage of 22 kV was then applied to 8 point electrodes of a mean radius about 10 μm in SF₆, N₂ and SF₆/N₂ mixture with oxygen traces pressurized at 6 bar absolute. The voltage across the discharge gap was continuously monitored and the current maintained at 100 μA. The variable parameters were the following : nature of the gas (nitrogen, SF₆, SF₆/nitrogen mixture with 10 % SF₆), temperature (20 °C, 60 °C), partial discharges formation time (10h to 40 h), percent-by-volume of oxygen (300 ppmv, 3000 ppmv).

3. Analysis of SF₆/N₂ mixture by-products

After the production of partial discharges in electrical insulation gases, we have proceeded to quantitative measurements of SF₆ and N₂ by-products with a precision of 5 % :

-The SF₆ by-products (SO₂, SOF₂, SO₂F₂...) have been analysed by gas chromatography with a detection threshold of about 10 ppmv;

The nitrogen by-products have been dosed by chemiluminescence with a detection threshold of 1 ppmv.

4. Experimental results

4.1 Effect of the partial discharges formation time in SF₆/N₂ mixture with 10 % SF₆ and 3000 ppmv Oxygen

The concentration of the Oxifluoride SO₂F₂ increase with partial discharges formation time from 10 to 40 hours. The total amount of toxic products is as more important as the P. D. formation time is long (Figure 2).

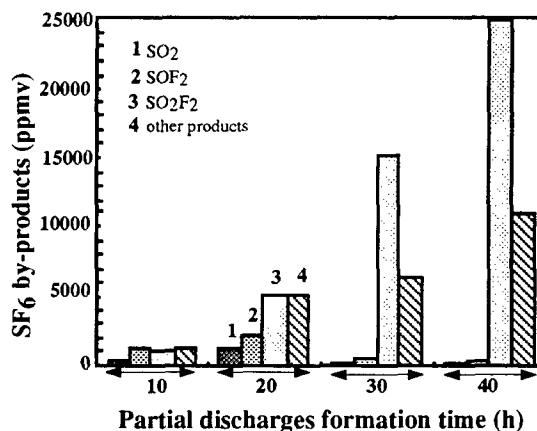


Figure 2. Effect of the P.D formation time in SF₆/N₂ mixture

4.2 Effect of the percent-by-volume concentration of oxygen in SF₆/N₂ mixture with 10 % SF₆

The percent-by-volume of oxygen from 300 ppmv to 3000 ppmv in SF₆/N₂ mixture with 10 % SF₆ seems to have some significant effects on the formation of SF₆ by-products (Figure 3). We can notice that the total amount of oxygen in oxifluorides is more important than the concentration of oxygen we added in the SF₆/N₂ mixture before the P.D. formation : traces of water may also contribute to the oxifluorides formation.

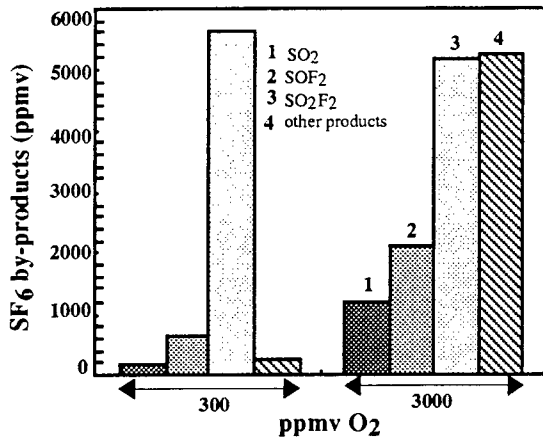


Figure 3. Percent-by-volume of SF₆ by-products in SF₆/N₂ mixture with 300 and 3000 ppmv O₂

4.3 Effect of temperature in SF₆/N₂ mixture with 10 % SF₆ and 3000 ppmv oxygen

The temperature between 20 °C and 60 °C in SF₆/N₂ mixture with 10 % SF₆ and 3000 ppmv oxygen seems to have significant effect on the SF₆ by-products (Figure 4).

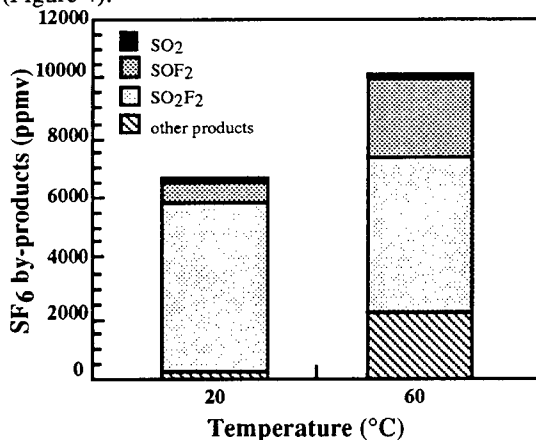


Figure 4. Percent-by-volume of SF₆ by-products in SF₆/N₂ mixture at ambient temperature and 60°C.

4.4 Effect of the nature of electrical insulation gas

Two gases have been studied : SF₆/N₂ mixture with 10% SF₆ and 3000 ppmv oxygen, nitrogen with 3000 ppmv oxygen. The P.D. formation has been done during

20 hours at 60 °C. The following results have been obtained :

-N₂ : about 70 ppmv of toxic products (NO, NO₂);

-N₂/SF₆ : about 4000 ppmv of toxic products.

We can notice that the total amount of SF₆ toxic by-products is about 50 times the N₂ toxic by-products.

We can also mention that SF₆ can lead to the formation of a very toxic product : S₂F₁₀. The very low quantity of this last product did not allow us to detect it by gas chromatography.

5. Conclusion

The experiments on partial discharges formation in SF₆/N₂ mixture with traces of oxygen have showed that the predominant by-products are the oxifluorides SOF₂, SO₂F₂ and SO₂. These by-products tend to increase with the partial discharges formation time and are stable. So, they induce a toxicity that is as more important as the P.D formation time is long. We could recommend to limit the formation of partial discharges in SF₆ gaseous insulated electrical equipments because several SF₆ by-products are very toxic.

6. References

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The Experimental Study of the Relaxation Processes in He with Admixture of O₂

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Introduction and experiment

Very effective tool for study of elementary processes in low temperature plasma is flowing afterglow (FA) technique. The flowing afterglow Langmuir probe (FALP) apparatus can be used to study kinetics of elementary processes where electrons take place. The High Pressure Flowing Afterglow (HPFA) apparatus used in presented experimental study is of the FALP type and was constructed to operate with buffer gas pressure up to 20 Torr. The apparatus consists of a glass discharge tube with microwave cavity discharge, adjacent metallic flow tube (30 cm long, 16 mm internal diameter) with axially movable Langmuir probe and mass spectrometer. The carrier gas, He in the present experiments, is purified by liquid nitrogen cooled molecular sieve trap. The plasma which is created in the microwave discharge is then carried down the flow tube with velocity 50m/s. 5cm along the flow tube corresponds to 1 ms of the decay time of the plasma. Immediately downstream from the discharge region Ar is added to the flow tube in order to remove metastable atoms and molecular He₂⁺ ions (for details see ref. [1]). At the beginning of the "reaction region" He⁺/Ar⁺ plasma is created. Via the entry port, situated 10 cm down stream from the discharge region, oxygen is added to the decaying plasma. The position of the reactant port is below referred as L=0. Typical electron temperature T_e(L=0) ≈ 0.04 eV and electron number density N_e(L=0) ≈ 1·10¹⁰ cm⁻³. The principal diagnostic tool in HPFA is the Langmuir probe (14 micron in diameter and 4 mm long), which is used to measure N_e, T_e, and to determine electron energy distribution function f_e(E) along the length of the column of the decaying plasma. The N_e is determined from the slope of a plot of the square of the probe current versus the probe voltage. The f_e(E) are calculated from the measured second derivative of the probe current, i, against probe potential, U, i.e. d²i/dU². A linear plot of log of d²i/dU² against U is indicative of a Maxwellian f_e(E); more generally the form of the plot indicates the actual f_e(E). If f_e(E) is not Maxwellian we use "effective" temperature, denoted as T_{eff}, to characterize the body of the distribution. T_{eff} is determined from the slope of the linear part of the semilogarithmic plot of measured second derivative (indicated by lines in the upper panel of Fig. 3).

Results and discussion

When O₂ is added to the flow tube (at L=0) He⁺ ions are rapidly converted to O₂⁺ and O⁺ ions. In the fast secondary reactions O⁺ ions are converted also to O₂⁺. The reaction of Ar⁺ with O₂ is slow. The formed O₂⁺ ions recombine with electrons. This recombination is fast because the electron

density is high, N_e(L=0) ≈ 1·10¹⁰ cm⁻³. In Fig. 1 is plotted N_e against the flow rate of O₂ for three fixed positions of the Langmuir probe (positions 6, 10, and 14 cm corresponds to 1.2, 2, and 2.8 milliseconds of the reaction-decay time, respectively).

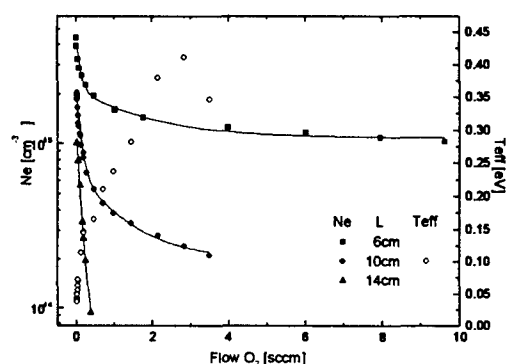


Fig. 1: The decay curves - decrease of the plasma concentration due to addition of O₂ (p_{He}=11.7 Torr, flow rate Φ_{He}=4550 sccm).

The rate of the observed rapid decrease of N_e is determined by the rate of the reaction of Ar⁺ with O₂. The obtained reaction rate k = 5·10⁻¹¹ cm³s⁻¹, this value is in good agreement with previous data (see compilation in ref. [2]). Only the fast decrease at the beginning of the decay curves, was considered in the determination of k, slow decrease at higher flow rate of O₂ is influenced by several processes and analyses of the data is more complicated. The measured T_{eff} is also included in the Fig. 1, note fast increase of T_{eff} with increasing flow rate of O₂. The recombination preferentially removes slow electrons from the plasma and the average energy of the electrons is increasing, indicating that relaxation processes are not enough effective in order to cool down plasma. The measurements of the plasma parameters along the flow tube, at constant flow of O₂, give further information about processes involved. In the upper panel of the Fig. 2 are plotted the plasma potential, V_{pl}, and the floating potential, V_f, as a function of the location - distance, L, from the reactant port. In the lower panel of Fig. 2 is plotted the measured N_e against L. Rapid decrease of N_e due to the recombination corresponds with the rapid increase of V_{pl}, and T_{eff}. The exponential decay at L ≥ 2.5 cm (linear part in semilog plot, lower panel of Fig. 2) indicates that the dominant loss process is diffusion.

More detailed information concerning role of the energy of electrons in this "chemically active He-O₂ plasma" is given in Fig. 3, where measured d²i/dU² and f(E) are plotted. Note

that the obtained electron energy distribution functions are not Maxwellian. $f_e(E)$ is close to Maxwellian for $L \geq 2.5$ cm where diffusion is the dominant process. $f_e(E)$ measured at $L=3.25$ cm has local maximum at $E=0.8$ eV, we assume that it is due to production of electrons in associative Penning ionization of remaining Ar metastables.

The presented experimental results will be used for verification of the model describing processes in He-O₂ plasma.

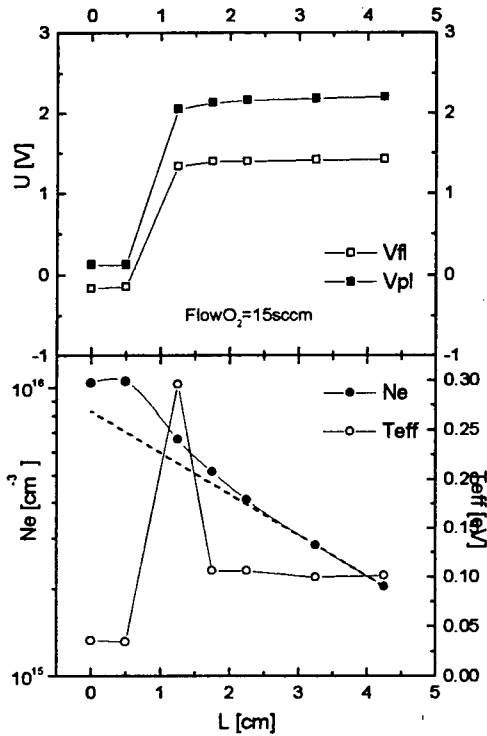


Fig. 2 Evolution of the plasma parameters along the flow tube ($p_{He}=11.7$ Torr, flow rate $\Phi_{He}=4550$ sccm).

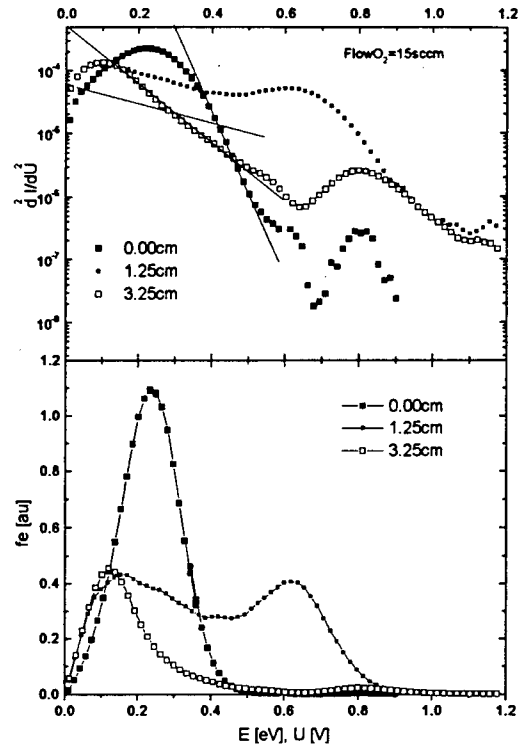


Fig. 3 Upper panel: The second derivative of the probe current, d^2i/dU^2 , i , against probe potential, U in different positions along the flow tube.

Lower panel: The evolution of the electron energy distribution function, $f_e(E)$, along the flow tube, normalized to electron number density, N_e .

Acknowledgement

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OZONE PRODUCTION IN CYLINDER-TO-CYLINDER PROXIMITY BARRIER DISCHARGES IN OXYGEN.

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Abstract: Ozone production is studied in cylinder-to-cylinder proximity discharges in oxygen at atmospheric pressure. Up to 5-6 W/cm³ of injected power density, the ozone yield increases with voltage amplitude and frequency to 180 g/kWh. Ozone concentration increases proportionally to the frequency up to 4 kHz.

1. Introduction

Different types of dielectric barrier discharges in various geometrical configurations (e.g. coaxial cylindrical or planar ones) are successfully used for ozone production. The role of the dielectric barrier is to prevent the streamer-to-arc transition and so to keep the plasma in low temperature conditions. Its presence implies the use of alternating voltages, with frequencies which have been varied from 50 Hz to 5 kHz [1]. To reduce the operating voltages, surface discharges [2] and dielectric pellets [3] were also used and investigations on a planar dielectric barrier discharge with minimised gaps performed [4]. An increase in ozone yield from 107 g/kWh to 150 g/kWh was found in the last case when decreasing the gap from 1.35 mm to 0.2 mm. Corresponding concentrations were not reported; it was only mentioned that a saturation appeared at 2.3 % vol. ozone for a gap of 0.2 mm [4].

A few years ago [5], dielectric barrier discharges in a cylinder-to-cylinder configuration with an insignificant discharge gap were developed in our laboratory. These discharges, called « proximity discharges », were at first studied at 50 Hz and then at higher frequencies, up to 2000 Hz [6]. The main advantage of proximity discharges, compared with other types of barrier discharges, is their low onset voltage.

2. Experiment

A dielectric barrier discharge between two Cu wire electrodes (respectively 1 and 2 mm diam., 40 cm length and put side by side in contact) covered with a polymer layer (20 μm thickness) was used as the ozonizer unit. The discharge gap was thus as small as possible on their line of contact and laterally increasing with the distance from this line outwards. These electrodes were placed inside a Teflon tube under flowing technical grade oxygen (99.9% purity). No additional drying was used. The reactor walls, the injected gas and one of the electrodes were cooled; gas temperature at the exit of the reactor before switching on the discharge was 7 °C. Gas flow was 0.49 Ndm³/min and gas pressure 10⁵ Pa.

A digital memory storage oscilloscope type TDS 544 A from Tektronix was used for the determination of the

discharge power consumption, by means of the area of the Lissajous' figure, using the relation :

$$P [W] = \langle \text{area } U_x U_y \rangle [V^2] R_{HV} C_0 [F] f [Hz]$$

where f is the frequency of the applied voltage, R_{HV} the dividing ratio of the high voltage probe, C_0 the capacity used for current integration. The results were compared in our previous work [6] with those provided by multiplication of the discharge current by the voltage in instantaneous values. Values obtained are within an error range of $\pm 10\%$. The electrodes were supplied with an AC voltage of different frequencies between 50 Hz and 4 kHz. The high voltage generator was described in [6]. After onset (peak-to-peak applied voltage $U_{pp0} \approx 2.32$ kV), the discharge appears between the wires along their whole length. Coming out from the oscilloscopic measurements, the discharges are dominated by streamers, taking place in both half-periods of the applied voltage, according to which wire electrode is playing a role of anode. An intense capacitive current was observed, but no current synchronous with the voltage. Hence the measured power is mainly due to the streamer current and the power measurements can be used to evaluate the RMS streamer current by simply dividing the mean power by the RMS voltage.

Ozone concentration was measured by means of UV absorption using the 253.7 nm wavelength radiation with a Perkin-Elmer Lambda 15 UV-VIS spectrophotometer; two different gas cells (10 cm and 1 cm length) were used for low and high ozone concentration measurements respectively. These measurements were verified by IR absorption spectroscopy [6]; values were within an error range of $\pm 5\%$.

3. Results

With our electrode configuration and operating conditions, ozone production was seen to increase with the injected power up to a critical production limit of 0.15 g/h (corresponding power length density ≈ 2.5 W/m and concentration $\approx 0.3\%$ vol.), and only then the gas temperature starts to increase and the yield to decrease subsequently. Fig. 1 shows ozone concentration as a function of injected power (with variable applied voltage amplitudes and frequencies, that gives a large explored field). This ozone concentration proportionally increases with the

injected power :

$$[O_3]/[O_2] \cong \text{const} (U_{PP}, f) * P[W]^{(1.077 \pm 0.03)}$$

Below the critical production limit, gas temperature remains quite constant and the ozone energetic yield increases from 100 g/kWh up to 180 g/kWh with power density (fig. 2 presents the yield increase with voltage and frequency). Fig. 3 shows the ozone concentration vs. the mean streamer current for constant values of the applied maximal voltage U_{PP} (variable frequency f , $U_{PP}=\text{const.}$). The ozone concentration is seen to increase with the mean streamer current as:

$$[O_3]/[O_2] \cong \text{const} (U_{PP}) * I_{RMS} (f)^{(1.04 \pm 0.03)}$$

On the contrary, if the frequency f is kept constant (variable peak-to-peak applied voltage U_{PP}), the ozone concentration vs. the mean streamer current (fig. 4) can be expressed as :

$$[O_3]/[O_2] \cong \text{const} (f) * I_{RMS} (U_{PP})^{(1.45 \pm 0.1)}$$

4. Concluding discussion

Cylinder-to-cylinder proximity barrier discharges are produced in a variable gap, which varies from practically zero (during the discharge ignition) up to a length equal to several times the radius of the wires. With the increase of the applied voltage during half-periods, the discharge can expand to the whole inter-electrodes volume, the first streamers produced on the line of contact of the wires providing seeds for longer streamers to develop, between the wire electrodes farther out of this line. This is illustrated by figs. 3-4, which show that the ozone concentration increases more rapidly with the applied voltage than with the frequency.

The increase of ozone yield with the applied voltage amplitude (fig. 2), should be explained by the decrease of the power volume density with the lateral expansion of the discharge. Inversely, the critical limit in the ozone production (fig. 1) should be due to the high power volume density which reaches about 4 W/cm^3 at this limit.

Acknowledgements The authors gratefully acknowledge help received from Electricité de France with a financial support.

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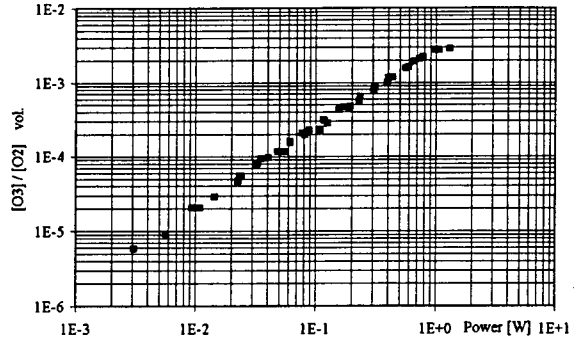


Fig. 1. Ozone concentration versus injected power.

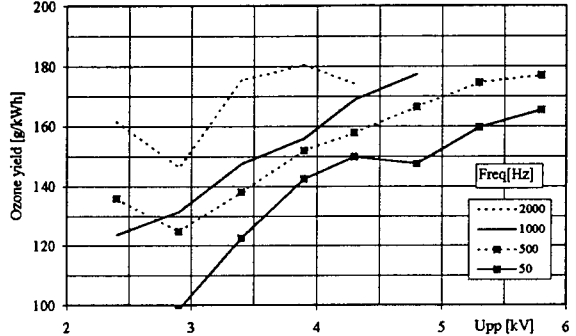


Fig. 2. Ozone energetic yield vs. applied maximal voltage U_{PP} and frequency f .

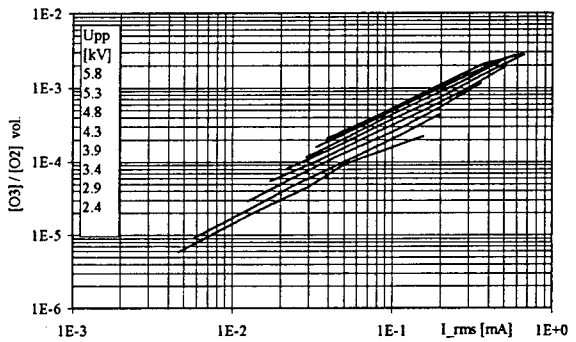


Fig. 3. O_3 concentration vs. I_{RMS} by varying f .

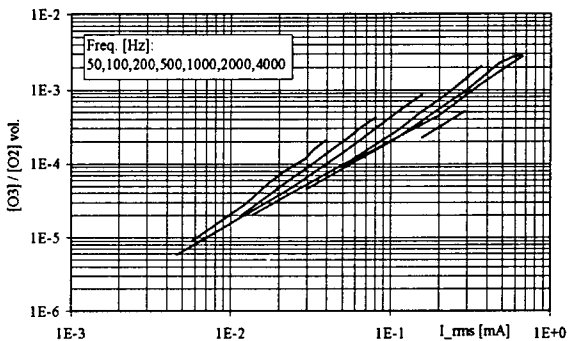


Fig. 4. O_3 concentration vs. I_{RMS} by varying U_{PP} .

Diagnostic of a plasma display panel cell : Spectroscopic and kinetic study. Electric study of light efficiency.

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Abstract

This work presents an experimental study of color AC plasma display panel cell. After the description of some flat display devices, we present a first study of spectroscopic and kinetic properties of the UV-Visible light. A second study deals with the influence of the composition of Ne-Xe and Ne-Kr-Xe mixture on light efficiency.

1. Introduction

Plasma display panels are flat display devices where the light of each picture element is emitted from plasma created by an electric discharge. The dimensions of the discharge can be in the 100 μm range at a pressure of a few hundred Torr. The performances of plasma displays have been constantly improved during three decades, and they are now serious competitors in the race of market of large size hanging high definition monitors.

Plasma displays [1,2] consist of two glass plates, each with parallel electrodes deposited on their surfaces. The plates are sealed together with their electrodes at right angles, and the gap between the plates is filled with rare gas mixture. Each picture element, at the intersection between a line and a column electrode, can be illuminated independently when a voltage pulse is applied between two electrodes. The voltage pulse leads to the electrical breakdown of the gas and to the formation of a weakly ionized plasma which emits UV light. This light is used to excite phosphors in the three fundamental colors. Rare gas mixture used are generally based on xenon, where photons emitted by $\text{Xe}^*(^3\text{P}_1)$ at 147 nm, upper vibrational levels of $\text{Xe}_2^*(^1,3\Sigma_u^+)$ at 173 nm are used to excite the phosphors.

2. Experiment

While applying the appropriate electric signal to the electrodes, the energetic electrons excite gas mixture atoms giving rise to an emission of UV photons lying in the [150-200 nm] range. This range of wavelength is covered by a monochromator in vacuum. Photons are detected using a photomultiplier working under low illumination conditions (single photoelectron method).

3. Study of the neon-xenon mixture

While the discharge occurs, an integrator allows the measurement of the discharge inherent current. Time evolution of the current pulse, for a given plasma display, is illustrated in Fig. 1. The pulse is very intense and very short (about ten nanoseconds).

Figure 2 presents the variation of luminescence for a Ne-Xe mixture. The UV light is emitted by xenon. The intensity of this light increases with the ratio of xenon. Figure 3 shows the influence of the ratio of xenon in the mixture on the light efficiency.

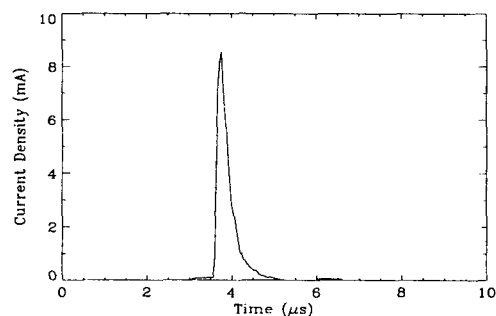


Fig. 1. Discharge current density of hundred cells, as a function of time for a discharge in a Ne-(10%)Xe mixture. Conditions: total gas pressure 560 Torr.

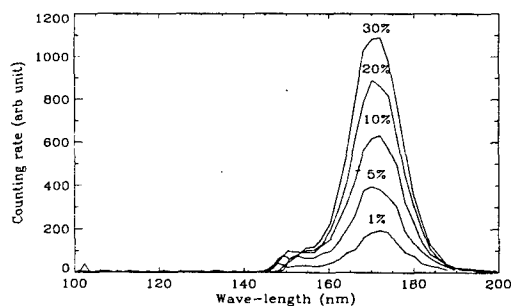


Fig. 2. Emissions spectra as a function of the ratio of xenon (same Conditions: as in Fig. 1).

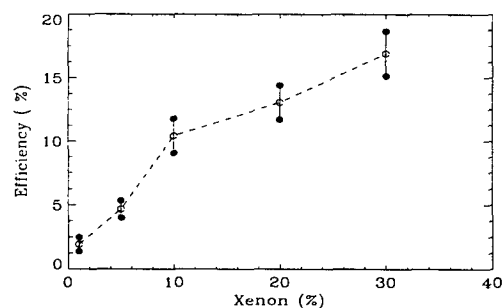


Fig. 3. Efficiency of the discharge in producing UV photons, as a function of ratio of xenon (same Conditions: as in Fig. 1).

Increasing the ratio of xenon improves the light efficiency but involves high electrical breakdown, leading to damages on the magnesium monoxide layer.

4. Study of Ne-Kr-Xe mixture

In order to improve the performances of the plasma display and to preserve the MgO layer from ionic bombardment, we study the effect of adding some krypton to Ne-Xe mixture on the electric and emission characteristics. Fig.4 presents the ternary mixture emissions spectra for various ratio of krypton.

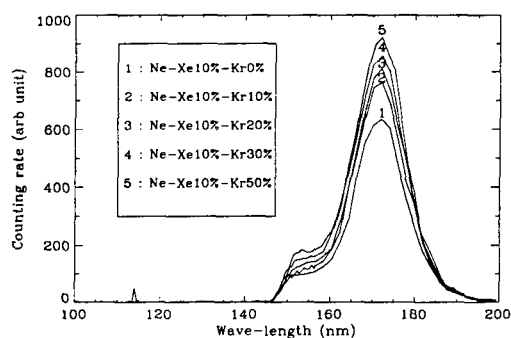


Fig. 4. Emissions spectra as a function of the percentage of krypton in Ne-Kr-Xe(10%) mixture; total gas pressure 560 Torr.

The observed emissions still correspond to xenon as a result of a transfert from the lighter gas to the heavier. Fig. 5. illustrates the influence of adding some krypton to a binary mixture, on light efficiency. Krypton improves light efficiency for 20 to 30%.

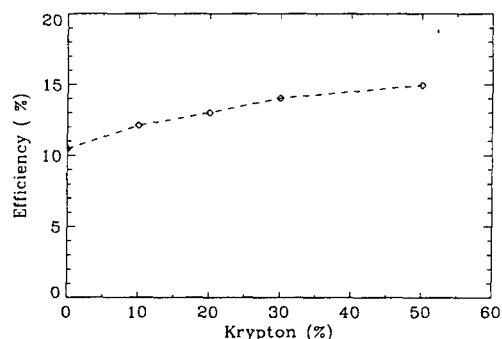


Fig. 5. Efficiency of the discharge in producing UV photons, as a function of percentage of krypton in Ne-Kr-(10%)Xe mixture; total gas pressure 560 Torr.

5. Study of Ne-Kr mixture

The study of the ternary mixture enlightens the fact that krypton improves the plasma display performances. The first stage consists in a study of the kinetic and spectroscopic properties of the Ne-Kr mixture. Then we focus on the ternary mixture, to finally end up with the modelisation of the middle. From the kinetic study, we derive a kinetic model for the involved reactions. Spectra of the Ne-Kr mixture are presented in Fig. 6. This time, the excitation source is radioactive (alpha) [Fig.6(a)].

The resulting spectra only show krypton emissions. The increase in krypton ratio leads to an enhancement of radiations. Similar results are obtained for an excitation of the middle by a plasma display [Fig.6(b)]. We conclude that luminescence and mode of excitation are independant.

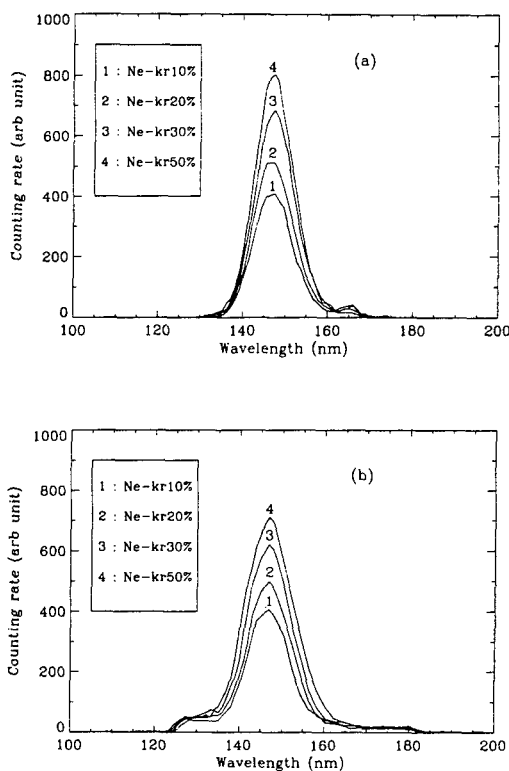


Fig. 6. Emissions spectra as a function of the percentage of krypton in Ne-Kr mixture; gaz pressure 560 Torr, excitation source (a) alpha particles (b) plasma display.

6. Conclusion

We have studied the electric and emission properties of the Ne-Xe mixture. Light efficiency increases with the ratio of xenon. In order to increase the lifetime of the plasma display, we have studied the influence of adding some krypton on the discharge. The kinetic study of the Ne-Kr mixture allows a modelisation of the ternary mixture. We are still carrying the study of the ternary mixture.

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The One Atmosphere Glow Discharge As A Sterilization Agent

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1. Introduction

This paper describes the generation of a uniform glow discharge at atmospheric pressure [1], and its use to effectively destroy microorganisms. The fact that no vacuum system is used to generate the discharge makes the apparatus very practical and inexpensive to build. Among the various potential industrial applications of this kind of plasma, investigations of its capability to sterilize contaminated matter, have been recently conducted [2]-[5].

2. Using the Discharge as a Sterilization Agent

Corona discharges and R.F. discharges have already been tested as sterilization means. However most R.F. discharges are operated at pressures below one atmosphere, and corona discharges have a small reactive volume, which renders them not suitable for large industrial applications. The One Atmosphere Glow Discharge, developed at the University of Tennessee Plasma Laboratory [1], combines the advantages of a large reactive volume, a relatively low input power, and the absence of a vacuum system.

The plasma in the One Atmosphere Glow Discharge (see Fig. 1) is generated between two plate electrodes, at least one of which is insulated by a dielectric material. The two electrodes are powered by a low frequency R.F. source (1 to 100 KHz). It is found that when the source frequency is within a narrow range, a uniform glow discharge fills up the gap between the electrodes. The frequency range is set by the gap distance between the electrodes, the applied RMS voltage, and the type of gas used. Outside this frequency range, the discharge becomes filamentary, or unstable. The typical input power is in the 50-150 W range, and the plasma power density, which is a function of the frequency and the RMS voltage, is in the 10-80 mw/cm^3 range. Usually, the electrodes setup is contained within an enclosure with a gas inlet port and an exhaust port. The discharge can be

operated in air, or a mixture of air and another gas such as helium, argon, etc... The gap between the electrodes is adjustable so as to accommodate the medium to be treated.

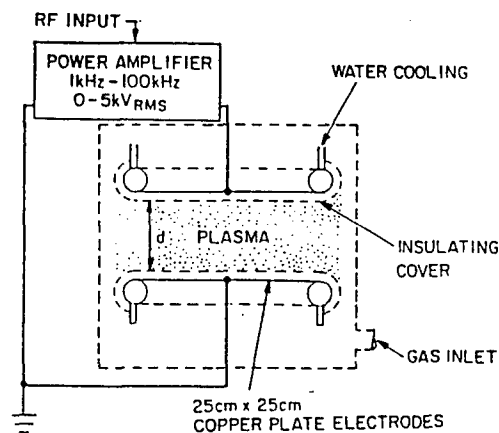


Fig. 1 One Atmosphere Glow Discharge Reactor

The plasma generated by the One Atmosphere Glow Discharge is a source of reactive free radicals, charged particles, and radiation. The free radicals interact with microbial cells at the molecular and atomic levels, inducing lethal changes to the chemical composition of the cells. Also, serious lesions and complete fragmentation of the cells have been observed. Hence, the discharge constitutes a very destructive environment for microorganisms with which it comes in contact. Laroussi et al. [2]-[4], and Ku et al. [5] have exposed various media contaminated by various types of bacteria. Sterilization was

achieved in less than 10 minutes in most cases, and in as low as 15 seconds in some cases.

The results obtained so far, indicate that the One Atmosphere Glow Discharge can be used as a sterilization apparatus. The absence of a vacuum system makes it practical and inexpensive, and the short treatment times makes it more versatile, more effective, and more practical than most presently used methods. Finally, this new method poses no environmental drawbacks, since no toxic byproducts or residues are generated in the process.

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Theoretical and experimental investigation of a discharge with liquid nonmetallic electrodes in air at atmospheric pressure.

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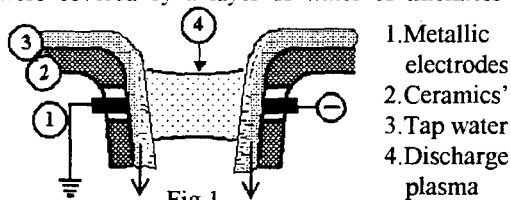
1. Introduction

The discharge with liquid nonmetallic electrodes (DLNME) has unique properties. It is self-maintaining discharge, which even at atmospheric pressure in air keeps the volumetric (diffuse) form of burning. DLNME till now is scanty investigated. The published results concern to discharge with one liquid electrode, as a rule with the liquid cathode [1]. The integral characteristics of discharge are measured mainly. The interest to researches of discharge is stimulated by opportunities of technical use [2] and in particular by prospect of use for the solving of such ecological problems, as monitoring of technical and waste waters composition, analysis and clearing of waste gas flows [3].

The present work aims at investigation of plasma parameters of discharge in the most simple for the analysis case - DLNME with electrodes from tap water.

2. Experimental technique

Discharge between two flows of tap water (fig.1) was investigated at d.c. $I \approx 50\text{mA}$ in air at atmospheric pressure. The metal anode was grounded. On the cathode there was the voltage $U \approx 3\text{kV}$. The ballast resistor $10\text{k}\Omega$ was used in series. The metal electrodes were covered by a layer of water of thickness 3mm.



Interelectrode gap (distance between water surfaces) was $L \approx 8\text{mm}$. The emission spectrum of discharge was registered with the spectral resolution $\approx 0.15\text{nm}$. Into discharge cylindrical probe $d=2a=0.3\text{mm}$ in diameter and 1mm length was short-term entered.

3. Experimental results and discussion

The discharge burns in volumetric (diffuse) form, diameter of the luminous channel is about 6mm. The axial dependence of probe floating potential V_f is shown on fig.2. We notice that discharge is non-uniform in an axial direction. Measured in a central

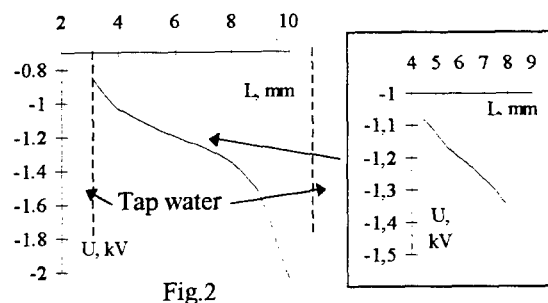


Fig.2

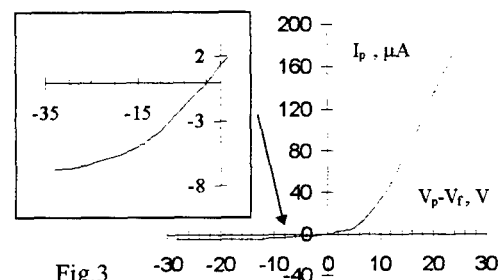


Fig.3

region of discharge volt-ampere probe characteristic is shown on fig.3.

Analysis of probe characteristic shows that current transfer in discharge is provided by electrons. The same result gives the calculation of plasma composition (see 4 Theory), according to which the concentration of negative ions is negligible, carriers of negative charge are electrons, and positive - ions NO^+ . The estimation of recombination length of NO^+ gives: $L_r \approx 10^{-3}\text{cm} \ll a$ (a - probe radius). Therefore at a collection of an electronic current the main contribution to a difference between potential of plasma V_{pl} and probe V_p is made by nondisturbed plasma area, in which current transfer has a drift character, in contrast with near probe layer, in which nonquasineutrality of plasma and diffusion of charges is essential. In this case probe volt-ampere characteristic at $V_p > V_f$ should be linear, as is observed in experiment. The theory [4] allows to determine from a linear plot conductivity of plasma and potential of plasma: $V_{pl} \approx V_f$. Thus it is possible to consider, that on fig.2 distribution of potential of plasma is shown and to determine an electrical field in the gap. The positive ion concentration was estimated from an ion current at $V_p < V_f$. The theory of probe ion current which accounts for ion generation in a probe layer was used [5].

The emission spectrum was measured in an interval (250-900)nm. In a spectrum the molecular bands of N_2 (2+system), N_2^+ and OH, and also spectral lines of atoms H, O and metal impurity contained in water were

observed. The second positive system of N_2 was used for determination of rotation T_{rot} and vibration T_{vib} temperatures, and relative intensity of lines H_α and H_β for an estimation of $T_{at.ex.}$ -atomic excitation temperature $T_{at.ex.}$ was determined in assumption of Boltzmann distribution on excited levels. Treatment of molecular spectra was carried out by comparing the recorded spectra with those calculated [6]. At all estimations we supposed, that the electron distribution function was Maxwellian, T_{vib} of a electronically-excited level $C^3\Pi_u$ of a N_2 was close to T_{vib} of the ground level. Lacks of such assumptions are obvious. The further work will be directed on derivation of the approach more adequate to examined conditions.

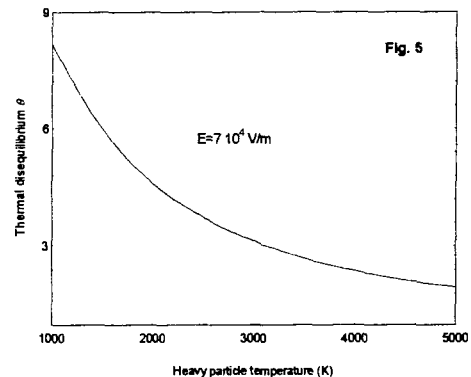
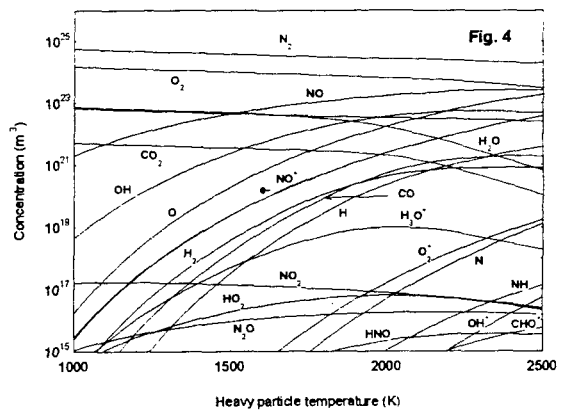
Results of measurements: DLNME consists of three approximately equal extent areas: cathode ($E \approx 4 \text{ kV/cm}$) and anode ($E \approx 2 \text{ kV/cm}$), the electrical field in which is variable along an axis, and column of discharge with approximately constant $E \approx 0.7 \text{ kV/cm}$. Concentration of charged particles in a column from an electronic branch of probe characteristic $n \approx (4 \div 6) \cdot 10^{11} \text{ cm}^{-3}$, from an ionic branch $n \approx (1 \div 2) \cdot 10^{12} \text{ cm}^{-3}$. The estimation from measured E/p and j gives $n \approx 10^{12} \text{ cm}^{-3}$. Temperature $T_{rot} \approx 1000\text{-}1500 \text{ K}$, $T_{vib} \approx 3000 \text{ K}$, $T_{ex.at.} \approx 4200 \text{ K}$.

4. Theory

If the pressure and the temperatures are maintained constant, the chemical equilibrium is reached when the Gibbs free energy is minimum. The Gibbs free energy depends on the concentration of the species. So with two other equations: Dalton law and electrical neutrality, we can determine the concentration versus the heavy particle temperature [7]. We can introduce a parameter theta that is the ratio between the temperature of free electron $T_{tr.e-}$ and the heavy particle translation temperature $T_{tr.h.}$ this parameter characterised the thermal disequilibrium. As regard the internal temperature we have made the following hypothesis: $T_{ex}^{diat} = T_{ex}^{at} = T_{tr.e-}$; $T_{rot} = T_{tr.h}$ and $T_{vib} = 2.5 \cdot T_{tr.h}$.

The figure 4 shows the composition for a thermal disequilibrium of 3.5 and for a mixture of 1 % water and 99 % of atmospheric air. We note that the electrical neutrality with the electron is done with NO^+ .

In a purpose to evaluate the thermal disequilibrium, we have equalized the energy gained in the electrical field by the electrons with the energy delivered during the collision of the electrons with the heavy particles [8]. We show the results in figure 5 for an electric field of $7 \cdot 10^4 \text{ V/m}$. The thermal disequilibrium takes a value included between 8.5 to 6 for a heavy particle temperature of 1000 to 1500 K.



5. Conclusion

The study of discharge with liquid nonmetallic electrodes is very complex. The first experimental results show that the electrical field is high ($\geq 0.7 \text{ kV/cm}$) and that the plasma is out of thermal equilibrium ($\theta \geq 3.5$). The composition calculation seems to give results in accordance with those experimentally obtained but this is not the case of thermal disequilibrium calculation. So this calculation have to be upgrade.

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Electrical behavior of a Dielectric Barrier controlled Atmospheric Pressure Glow Discharge

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The objective of the present study is to better define the behavior of a glow discharge controlled by a dielectric barrier and obtained at atmospheric pressure [2, 5]. The intended application is for a homogeneous treatment of polypropylene films in view of increasing its wettability and its adhesion.

1. Experimental conditions :

In a discharge cell, [1, 4], the glow discharge is obtained between two dielectric-covered plane electrodes.

Before filling the discharge cell with helium (Air liquide, type C), a primary vacuum is created. The residual pressure is 0.1 Pa. A generator coupled to a transformer delivers a voltage having a maximum r.m.s. value of 1640 V. In addition, as shown in figure (1) a capacitor "C_p" is connected in parallel with the transformer.

In this configuration, assuming that the discharge is homogeneous and that the section is equal to the surface area of the metalization, one can consider that there exists a capacitor on either side of the ionized gas column. Their plates are represented on the one hand by the metalization of the dielectric placed on the electrodes and on the others by the surface on which the charges are deposited.

Six parameters have been studied. They concern the electrode configuration (gas gap "d" and the capacitance of the solid dielectrics between electrodes "C_{ds}") or the excitation and the electrical circuit (voltage applied "V_a", excitation frequency "f", series resistance "R_s" and parallel capacitance "C_p") [Fig. 1].

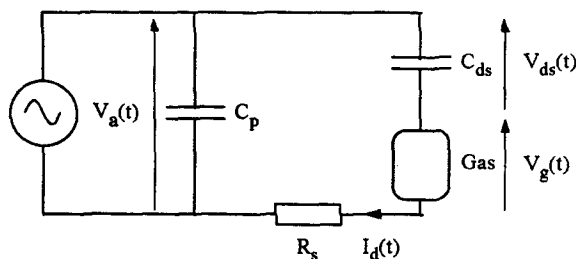


Fig. 1 : Electrical circuit diagram.

The effect of each of these parameters has been studied keeping the rest as constant at the following values ($f = 10$ kHz, $d = 5$ mm, $V_a = 800$ V, $C_{ds} = 70$ pF, $C_p = 350$ pF, $R_s = 47 \Omega$ et $P_r = 0,1$ Pa). The entire set of these values, so called "standard", have been defined beforehand with the help of criteria which are the

wettability of the polypropylene surface and the homogeneity of the treatment.

2. Measurements and electrical equations:

The electrical characterization of this discharge consist of the measurements of two variables : the discharge current "I_d(t)" and the applied voltage on the entire set composed of the dielectrics and the gas "V_a(t)" [3, 1].

The current is measured with a resistance. Current and voltage measurements are performed with the help of an oscilloscope H.P. 54601A-100 MHz. From these two measurements performed over one time period, the voltages applied to the dielectrics "V_{ds}(t)" and to the gas "V_g(t)" are calculated according to the equation below :

$$V_a(t) = V_g(t) + V_{ds}(t) \quad (\text{Eq. 1})$$

$$V_{ds}(t) = Q(t)/C_{ds} + V_{ds}(t_0) \quad (\text{Eq. 2})$$

$$Q_d(t) = \int_{t_0}^{t+t_0} I_d(t) \cdot dt \quad (\text{Eq. 3})$$

V_{ds}(t₀) : Solid dielectric voltage at the time t = t₀.

$$V_g^*(t) = V_g(t) + V_{ds}(t_0) \quad (\text{Eq. 4})$$

$$\overline{V_g^*} = 1/T \int_{t_0}^{T+t_0} V_g^*(t) dt = V_{ds}(t_0) \quad (\text{Eq. 5})$$

3. Results and discussion :

When the discharge is of a glow type, a single current pulse is observed on each half period. The discharge current is periodic and a small current peak is observed when the voltage applied to the gas is reversed [3]. In addition, even if the electrode configuration is symmetrical, which is the case of the results given here, a current desymmetry is observed between the positive and the negative alternations. The amplitude of the difference between two successive alternations is limited. Indeed, when the desymmetry becomes important, a reversal of the properties of the positive and negative alternations is observed. The correlations have been brought into evidence when the current amplitude before initiation is high, the maximum current amplitude and the ignition voltage are high too while the minimum voltage is small [Fig. 2].

Under standard experimental conditions, the average values and the difference measured between the positive and the negative alternations are : a current density of the order of (2.5 ± 1.6) mA.cm⁻², a density of

the charges displaced per period of $(23 \pm 0.5) \text{ nC/cm}^2$, a geometrical field at ignition of $(2.5 \pm 0.4) \text{ kV.cm}^{-1}$, a minimum voltage of $(150 \pm 150) \text{ V}$.

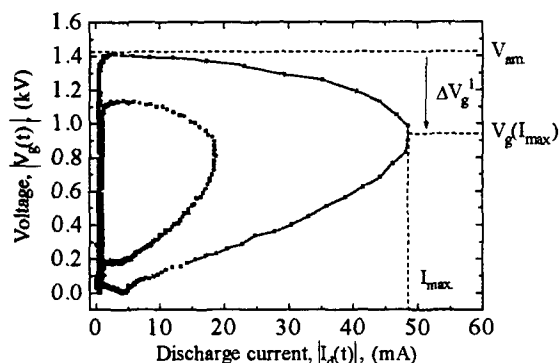


Fig. 2 : Absolute value of the gas voltage as a function of the absolute value of the discharge current ($f = 10 \text{ kHz}$, $d = 5 \text{ mm}$, $V_a = 800 \text{ V}$, $C_{ds} = 70 \text{ pF}$).

We have shown earlier [3], the importance of the residual charge density before ignition. They are the charges which explain the desymmetry. If this density is high, the number of ionizing collisions under a weak field increases and the breakdown voltage is small. The discharge develops slowly and the maximum-current has a small amplitude. The charge deposited on the dielectrics is, in this case, relatively low and it induces a small drop of the gas voltage in such a way the voltage minimum remains high. The charges are then effectively drained towards the electrodes, this effect together with the small number of charges generated leads to a small residual charge density during the next ignition. In those conditions the following ignition requires a higher breakdown voltage which results, at the same time, in a current peak of higher amplitude, a rapid fall in gas voltage, a small minimum voltage and a small flow of charges after the current peak. When the residual charge density remains important, an ignition under a weak field is then observed during the next alternation.

The charge density remaining during the initiation of a discharge depends, at the same time, on the density of the charges generated during the preceding discharge and the manner in which the charges are drained, as well as on the time separating the reversal of the gas voltage from the initiation of the discharge. This last point permits to explain the property reversals of positive and negative alternations for an important desymmetry. This is observed when the polarity reversal of the electrodes occurs too soon. As a matter of fact, an intense current peak helps maintain an important charge density in the gas, between two current impulses. However, if after the discharge the gas voltage is small, the polarity changes as soon as the applied voltage starts to fall. At this instant, the current being small, the variation of the gas voltage is equal to the variation of the applied voltage. If the latter varies

slowly, the gas voltage varies slowly, this being the case near the peak values of the sinusoid. In this case, the time between the reversal of the gas voltage and the discharge initiation is greater than in the case where the gas voltage changes sign as the applied voltage starts to fall. Hence, if the gas voltage changes polarity as soon as the applied voltage starts to fall, the electrons will have more time to flow before the initiation of the discharge. This leads to a decrease of the electron germ density in the gas during the next initiation and thus, to an intense current peak in the alternation which corresponded to a small amplitude current.

We have drawn in figure (3) the evolution of the average value of the gas voltage obtained at maximum current " $V_g(I_{max})$ ", as a function of the average value of maximum-current over one period " I_{max} ", for different parameters under study.

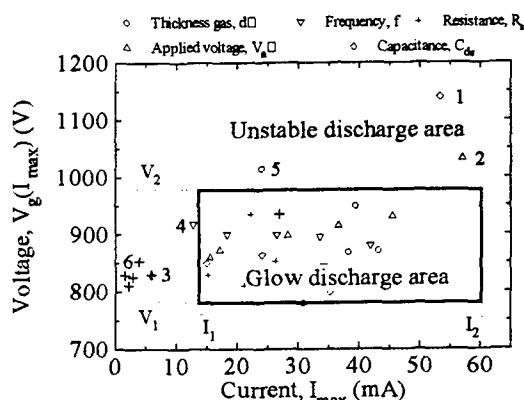


Fig. 3 : Evolution of the average gas voltage at maximum current as a function of the average maximum-current amplitude.

In addition, we have reported the maximum (V_2 , I_2) and minimum (V_1 , I_1) values observed for positive and negative alternations, obtained under standard conditions. These values demarcate a rectangle. We note that by varying the parameters we can not alter the characteristics of the gas beyond what could be observed under standard condition, without modifying the diameter and the discharge régime. When this experimental conditions furthers from the optimal condition, the discharge becomes symmetrical.

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The influence of the surrounding atmosphere on plasmas sustained by the "Torche à Injection Axiale"

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1. Introduction

The microwave torch named "Torche à Injection Axiale" (TIA), i.e. torch with axial gas injection, was developed by the group of Moisan in 1993 [1]. A schematic of the TIA is depicted in Figure 1. This plasma torch can, depending on the geometry of the nozzle (cf. Figure 2), excite many kinds of gases or mixtures, such as air, CO₂ and noble gases. Therefore, it is a very promising plasma source for spectrochemical purposes [2]. The plasmas sustained by the TIA normally expand in the open air and are typically 10 cm long and 2 mm in diameter. Microwave powers up to 2 kW can be used without the need for external cooling. In a previous paper we presented the electron density and temperature determined by Thomson scattering [3]. In a plasma with helium as main gas n_e ranges between 0.64 and $5.1 \times 10^{20} \text{ m}^{-3}$ and T_e is around 25000 K. In an argon plasma the electron temperature is lower and the electron density is higher: 17000 K and around 10^{21} m^{-3} respectively. In both cases the original nozzle is used.

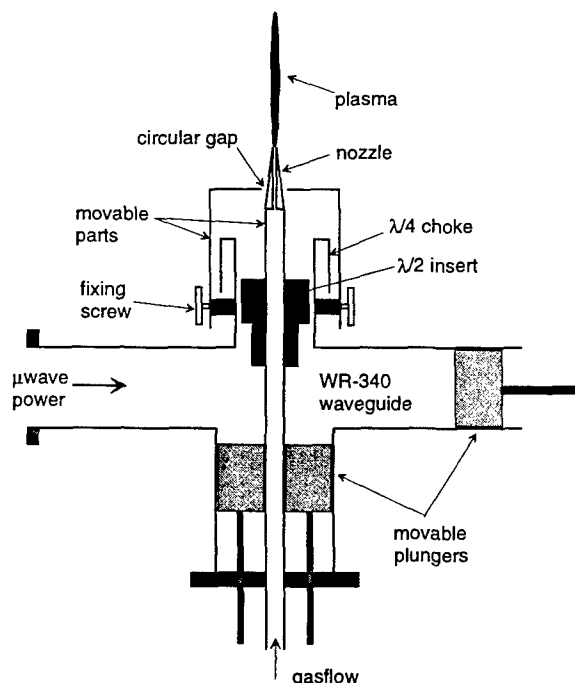


Figure 1: The TIA consists of a coaxial waveguide perpendicular to a standard rectangular waveguide. Due to its specific design the matching is very insensitive for changes in plasma parameters like applied power and gas flow [1].

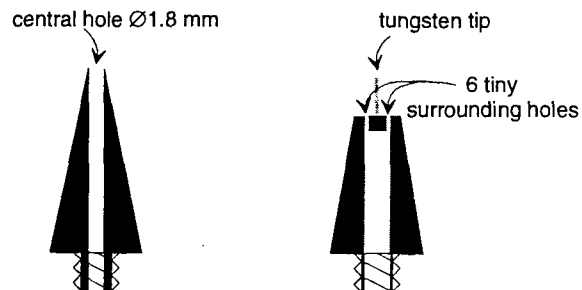


Figure 2: Two possible nozzle geometries of the TIA. On the left the original nozzle proposed by Moisan et al. [1] is depicted; on the right the one by Ricard et al. [4].

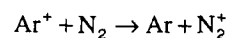
Using these Thomson scattering results, it can be established that the ionisation rates of both plasmas are much larger than the recombination rates, which means that the plasmas are far from Saha equilibrium. However, the production of new ions and free electrons outranges by two orders the estimated "classical" losses due to flow and diffusion [5].

Radially resolved Thomson scattering measurements on this small plasma show that it has a hollow structure [5]. This means that the diffusion losses were originally underestimated, since the steep outer gradients enhance the losses due to diffusion. Taking these losses into account the high electron temperatures in the helium plasma can be explained. But in the argon plasma the higher diffusion rate can not balance the ionisation rate, which remains one order of magnitude higher [5].

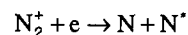
This means that there is a fourth process (besides diffusion, flow and recombination) which can not be neglected. This contribution deals with one possible process: mixing with the surrounding air.

2. Theory

If the surrounding air is mixed with the argon plasma an extra destruction channel for the ions and free electrons is created, i.e. charge transfer with nitrogen



followed by dissociative recombination



The charge transfer reaction is resonant since the ionisation energies of argon and molecular nitrogen are almost equal (15.76 and 15.58 eV respectively). The second reaction is fast due to the attractive Coulomb interaction between the positively charged molecule

and the electron. The presence of this mechanism is supported by the fact that in these plasmas the First Negative system of N_2^+ and many atomic nitrogen lines can be observed [2,4]. Moreover, a significant entrainment of air into an ICP, which is also expanding in the open air, was measured by de Regt et al. [6]. If we assume that 1% of the heavy particles in the plasma are nitrogen molecules this destruction channel can be fast enough to balance the ionisation. However, the remaining excited atom can be easily ionised again. Therefore the significance of such kinds of mechanisms has to be investigated by controlling the atmosphere in which the plasma expands.

3. Experimental

A special vessel is constructed around the coaxial top of the TIA and on top of the rectangular waveguide. The coaxial structure itself is sealed using a teflon ring. The vessel is flushed with either argon or nitrogen. Using the same high resolution Thomson scattering setup [5], the electron density and temperature are measured as function of the radius and the height above the nozzle. A typical result is depicted in Figure 3. The plasma which is sustained in a nitrogen atmosphere is more or less the same as the one expanding in the open air. However in case the nitrogen is replaced by argon, the plasma becomes much larger (cf. Figure 3). This confirms that mixing with the surrounding gas is an important mechanism.

Using vibrational Raman scattering [6] the density of nitrogen molecules in the plasma is measured as function of the radius. Using these densities the destruction rate via the processes discussed in Section 2 can be determined and compared to the other loss processes. In this way quantitative information on the significance of the entrainment of air can be obtained.

In case the tungsten tip nozzle (cf. Figure 2) is used to sustain the plasma, the electron density appears to be much lower than in a similar plasma using the original nozzle [4]. This might be due to a more turbulent plasma which enhances the mixing with surrounding air. This is supported by the fact that the change between a nitrogen and an argon atmosphere is clearly visible with the naked eye.

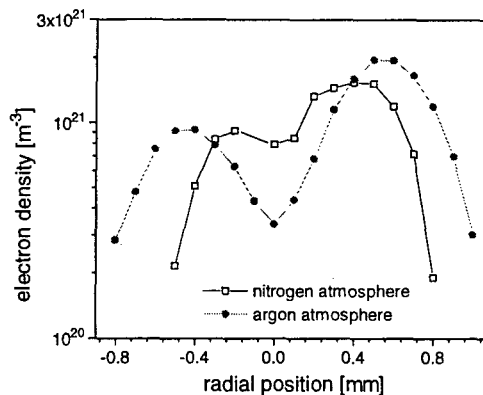


Figure 3: The influence of the surrounding atmosphere on an argon plasma created by the original nozzle.

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The role of He₂ molecules in plasma kinetics of high pressure helium fast discharges.

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Pulsed high-pressure discharges in noble-gas mixtures are of interest for a variety of technological applications which need ionization sources of samples in gas chromatography or efficient radiation in the VUV range. Well-known broad-band continuum emission of noble-gas excimers is caused by bound-free $B, A \ ^1,3\Sigma_u^+ \rightarrow X \ ^1\Sigma_g^+$ transitions. These transitions have perspectives for high-power VUV lasing media as well.

For the most of noble gases (Ne, Ar, Kr, Xe) the formation of excited dimer molecules in high pressure conditions is connected with relatively slow three-body association reaction (excited atom + two ground state atoms). Excited atoms are produced mainly after the fast dissociation recombination reaction of rare gas dimer ions and cold electrons in the early afterglow. The situation for helium plasmas, however, is far from being well understood up to now. Manifold of strongly bounded electronically excited molecular He₂⁺ states may play significant role in the excitation-recombination processes in high pressure conditions.

A serious applied problem for the long-term operation of VUV lasers and excimer lamps is contaminants created in a gas mixture due to discharge-induced chemical reactions between trace impurities and main gas components. Accumulated contaminants not only absorb VUV radiation but change significantly the excitation energy-flow kinetics and destroy the spatial homogeneity of the discharge. Development of new generation of "sealed-off" high-pressure gas lasers and excimer lamps with qualitative improvement of gas lifetime stimulates spectroscopic investigations of trace contaminants in noble-gas discharge plasmas.

The aim of this work is on-line monitoring of excited atomic and molecular helium species in high pressure helium discharge, investigation of key plasm-chemical reactions for their creation kinetics and influence of accumulated contaminants on these kinetics.

The object of our investigation is helium discharge plasma in commercially available miniature excimer laser PSX-100 (MPB Technologies Inc.). This laser operating as F₂ laser (gas mixture He/F₂, 6 bar / 5 mbar) gives pulse energy of about 1 mJ at 157.6 nm with repetition rate up to 100 Hz and gas lifetime of

10⁶ pulses. This laser operating as ArF excimer laser gives the output energy of 5 mJ at 193 nm.

In this work we report temporal and spectral emission (absorption) data from the discharge and afterglow stages of a high-pressure (3 - 9 bar) helium discharge plasma under the fast (~10 ns) high deposition power (~20 MW/cm²) excitation. Kinetics of spontaneous emission were measured through the monochromator by fast PMT and transient digitizer, while absorption kinetics were detected by pulsed (5 ns) tunable dye laser absorption probing technique. Dye laser was pumped by XeCl laser which was electronically synchronized with the investigated discharge. The computer-control delay generator triggered both lasers with an adjustable time-shift up to several microseconds.

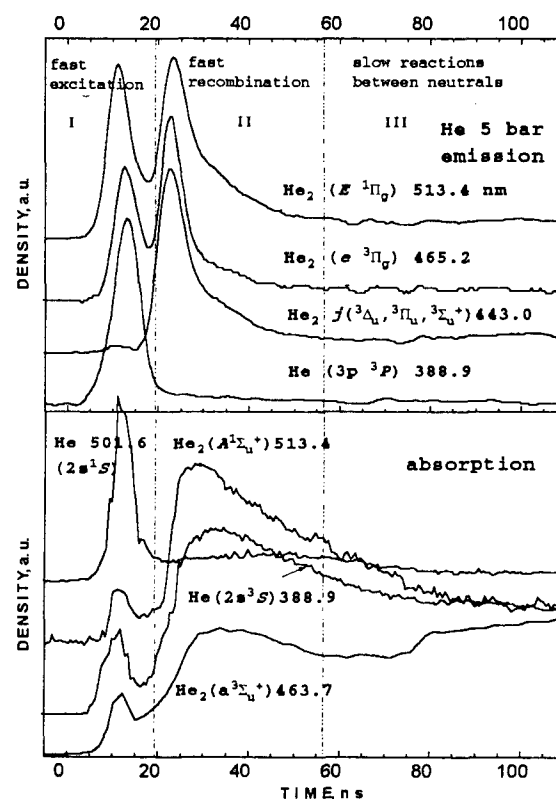


Figure shows temporal behaviors of the densities of some excited atomic He⁺ and molecular He₂⁺ species measured from spontaneous emission and

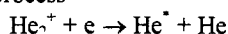
absorption kinetics in the discharge of pure helium at 5 bar pressure. The intensity of He atomic emission lines (the most intense is 388.9 nm line) decreases continuously with the growth of He pressure from 3 to 9 bar, while the intensity of He₂⁺ emission lines increases up to optimum pressure 6 bar and then declines depending on the impedance mismatching of the discharge plasma and the pumping circuit.

It is possible to identify three different stages in these kinetics:

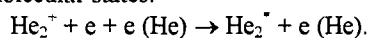
- I - the stage of fast discharge excitation,
- II - the stage of fast electron recombination,
- III - the stage of slow reactions between excited neutral species.

Atomic helium emission is observed only during the stage I when the temperature of electrons is high enough to excite He electronic states. He₂⁺ molecular electronic low-energy states ($E^1\Pi_g$, $e^3\Pi_g$) are excited very effectively during the first stage by the direct electron impact excitation of quasibounded helium molecules (the pairs of helium atoms which are distributed on the repulsive He-He interaction $X^1\Sigma_g^+$ curve). The fraction of such helium atomic pairs grows as the square of helium gas density. In the pure helium gas the He₂ molecules play the role of additives which have lower excitation (ionization) potential compared with the atomic helium.

As concerning high-energy He₂⁺ molecular electronic states ($^1\Delta_u$, $^3\Pi_u$, $^3\Sigma_u^+$) there is only small emission maximum in the first stage caused by the direct electron impact excitation of helium molecules. However, the emission maxima in the recombination stage II of the discharge are nearly the same for all measured He₂⁺ emission bands. This shows that together with well-known for noble gases dissociative recombination process

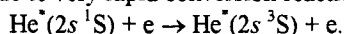


significant recombination flow is realized through the helium molecular states:



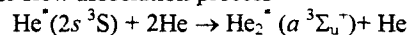
This recombination is very fast in our high pressure and high electron density conditions. We estimate the recombination rate of 2 - 20 ns (this estimation depends strongly on the temperature and density of electrons).

The maximum density of He⁺(2s¹S) metastables is about $3 \times 10^{14} \text{ cm}^{-3}$ and is observed in the first (excitation) stage of the discharge. However, the density of He⁺(2s³S) metastables achieves its maximum about $2 \times 10^{15} \text{ cm}^{-3}$ during the second (recombination) stage of the discharge. The density of He⁺(2s¹S) metastables in the recombination stage is very low due to very rapid conversion reaction:



The long tail in the absorption kinetics of He(2s³S) metastables (stage III) reflects their destruction

in rather slow association process



with the rate constant in our conditions of $3.5 \times 10^6 \text{ s}^{-1}$.

The longest decay kinetics ($\tau \approx 400 \text{ ns}$) in our discharge have He₂⁺($a^3\Sigma_u^+$) metastable molecules. Unfortunately oscillator strengths are unknown for molecular He₂⁺ transitions, so we can not calculate absolute densities of He₂⁺ species. Their lifetime is very sensitive to the presence of contaminants in helium gas. The following impurity radicals (CN⁺, CH⁺, C₂⁺, OH⁺), atoms (O⁺, C⁺, N⁺, H⁺), molecules (CO⁺, N₂⁺) and molecular ions (CO²⁺, N₂²⁺) are identified from time-resolved spontaneous emission spectra in the aged helium gas mixture [1]. Carbon radicals and carbon atoms show rather long emission decay kinetics which reflect chemical reactions between trace stable carbon-containing contaminants and high-energetic He₂⁺ molecular excimers in long-lived triplet electronic states.

The measured absorption spectra of $e^3\Pi_u \leftarrow a^3\Sigma_u^+$ and $E^1\Pi_g \leftarrow A^1\Sigma_u^+$ He₂ transitions were used to determine the rotational temperature during the stages II and III. The calculations show that the lower He₂ rotational levels ($J \leq 7$) are considerably colder ($T_{\text{rot}} = 400 \text{ K}$) than the higher rotational levels ($J > 7$) for $a^3\Sigma_u^+$ state ($T_{\text{rot}} = 4000 \text{ K}$) and for $A^1\Sigma_u^+$ state ($T_{\text{rot}} = 1500 \text{ K}$) if we suppose Boltzmann-like distribution with different rotational temperatures in these two groups of levels. Generally it means the prevailing population of high rotational levels by some reaction which is clearly demonstrated by the different temporal behaviors in absorption lines with low and high rotational quantum numbers J .

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